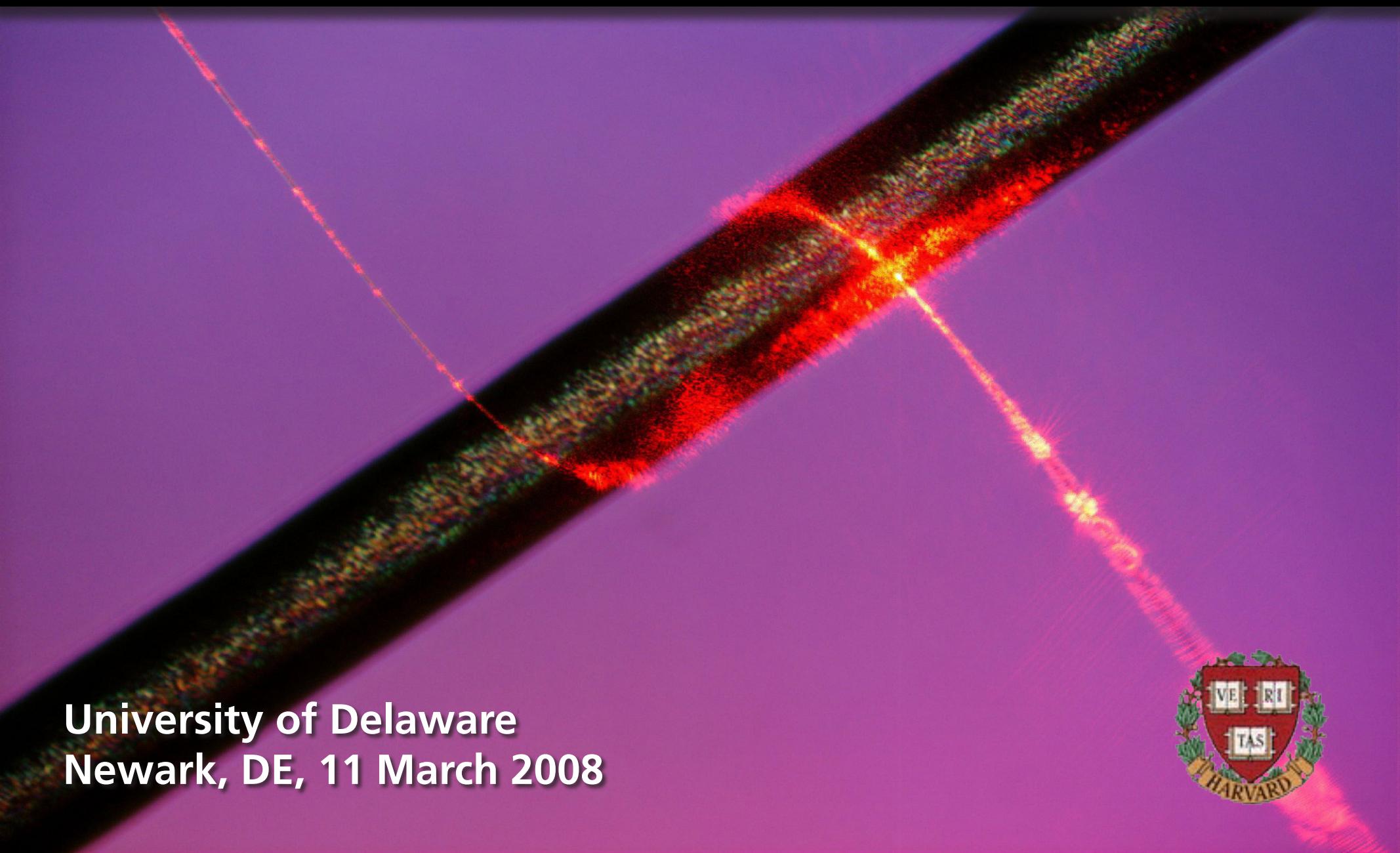
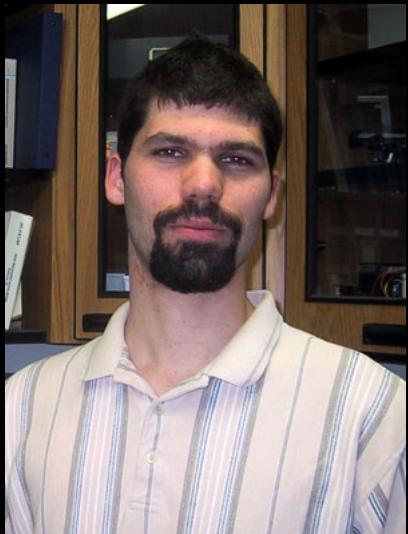


Wrapping light around a hair



University of Delaware
Newark, DE, 11 March 2008

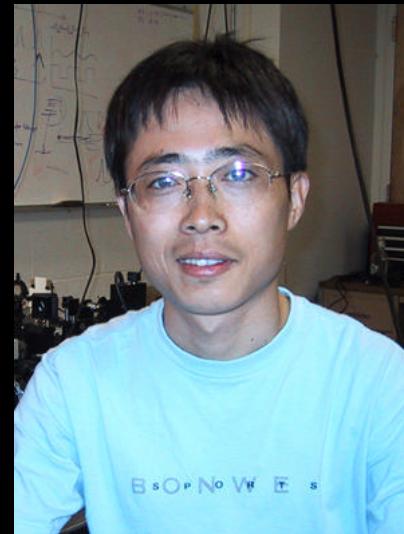




Rafael Gattass



Geoff Svacha



Limin Tong



Tobias Voss

and also....

Jonathan Aschom

Mengyan Shen

Iva Maxwell

James Carey

Brian Tull

Dr. Yuan Lu

Dr. Richard Schalek

Prof. Federico Capasso

Prof. Cynthia Friend

Xuewen Chen (Zhejiang)

Zhanghua Han (Zhejiang)

Dr. Sailing He (Zhejiang)

Liu Liu (Zhejiang)

Dr. Jingyi Lou (Zhejiang)

Dr. Ray Mariella (LLNL)

Prof. Frank Marlow (MPI Mühlheim)

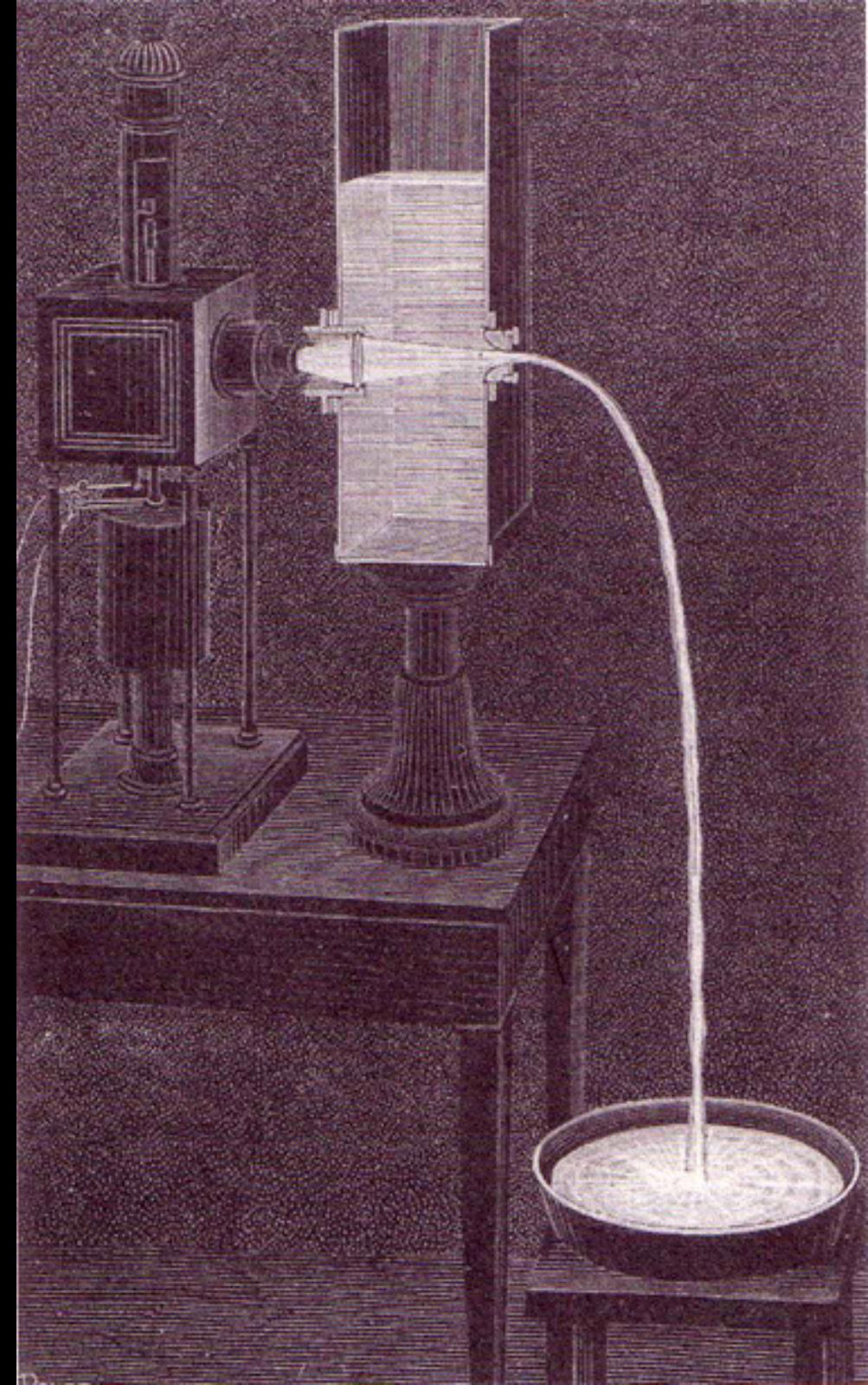
Prof. Sven Müller (Göttingen)

Prof. Carsten Ronning (Göttingen)

"I managed to illuminate the interior of a stream in a dark space. I have discovered that this strange arrangement offers one of the most beautiful, and most curious experiments that one can perform in a course on Optics."

Daniel Colladon, *Comptes Rendus*, 15, 800–802 (1842)

D. Colladon, *La Nature*, 325 (1884)





(nu model.)

4 Sheets—Sheet

W. WHEELER.

APPARATUS FOR LIGHTING DWELLINGS OR OTHER STRUCTURES.

No. 247,229.

Patented Sept. 20, 1881.

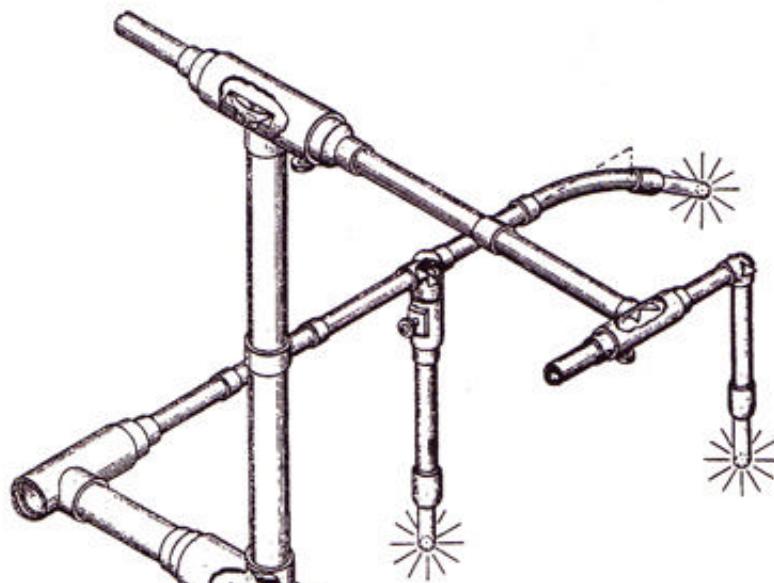


Fig. 2.

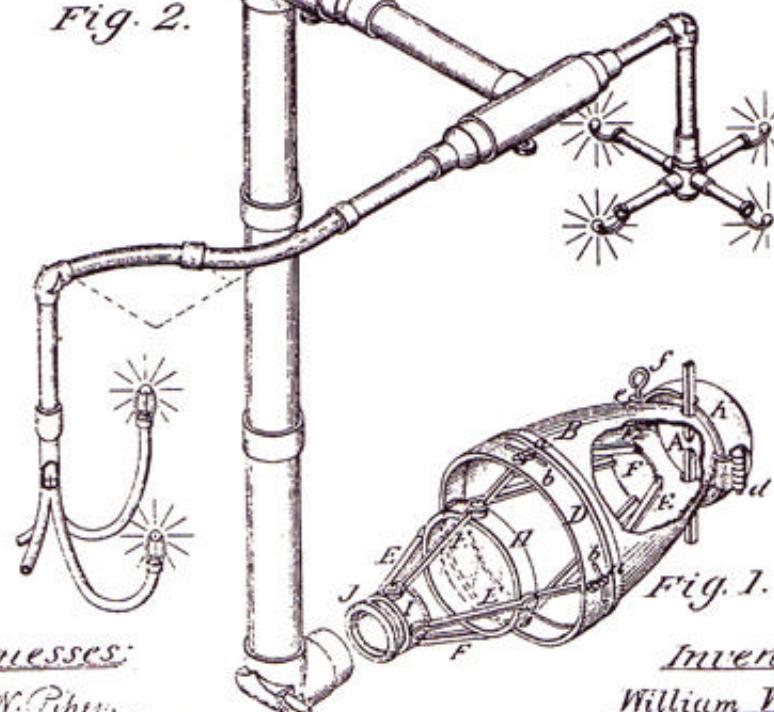


Fig. 1.

Witnesses:

S. N. Piper.

E. L. Pease

Inventor:

William Wheeler

by attorney

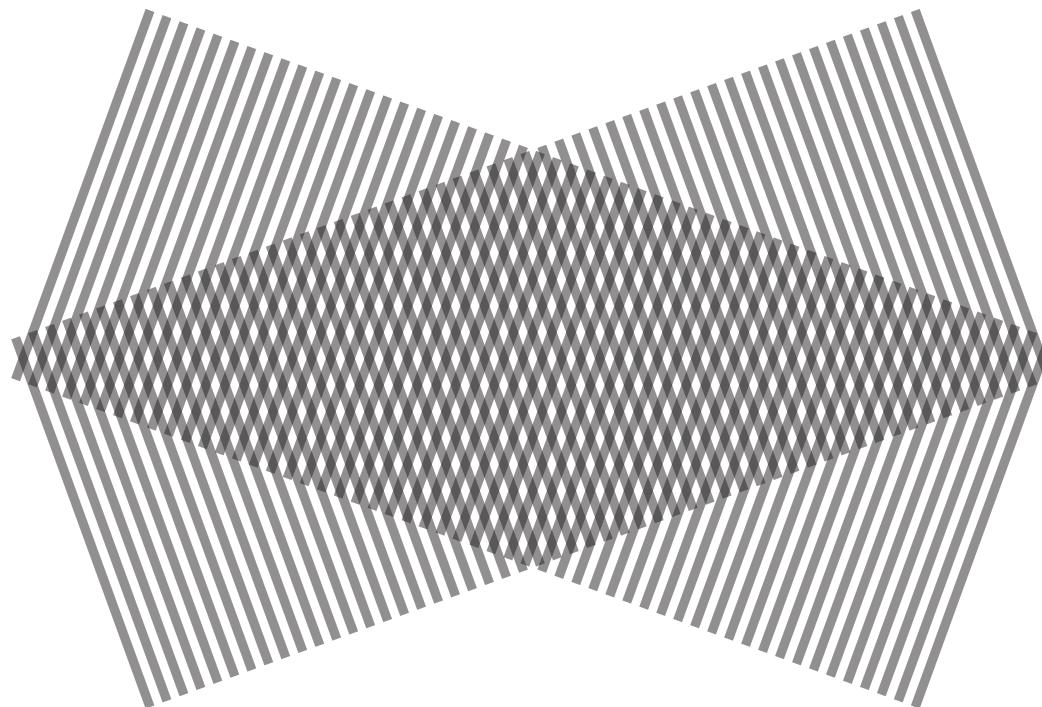
US Patent 247, 229 (1881)

Outline

- waveguiding
- silica nanowires
- manipulating light at the nanoscale
- nanoscale nonlinear optics

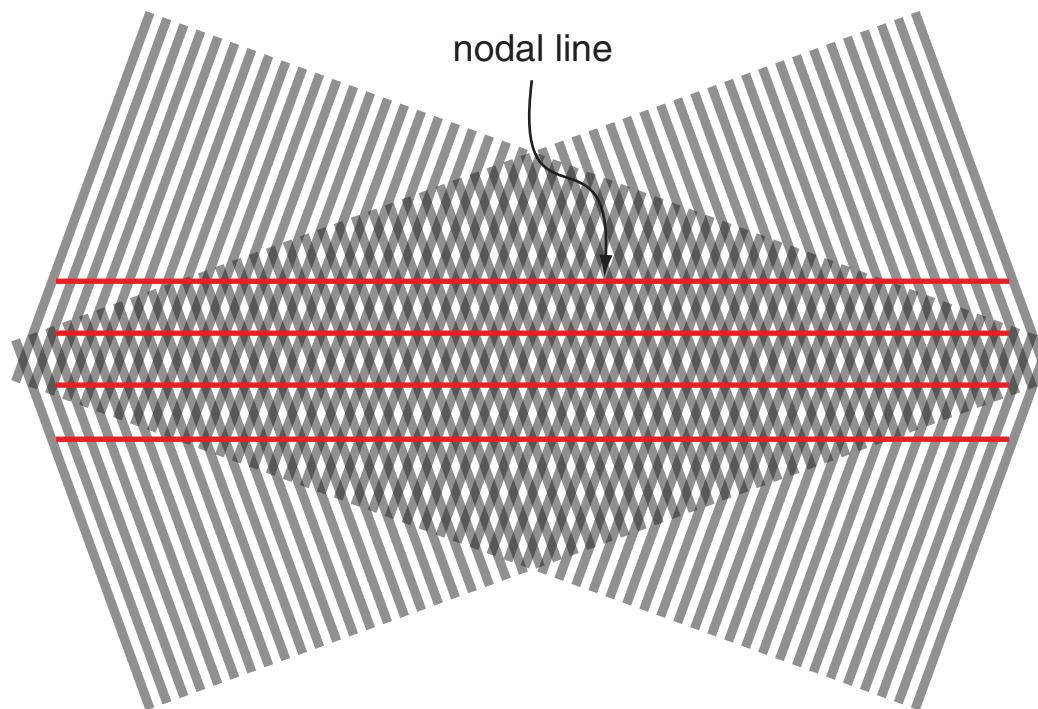
Waveguiding

two crossed planar waves...



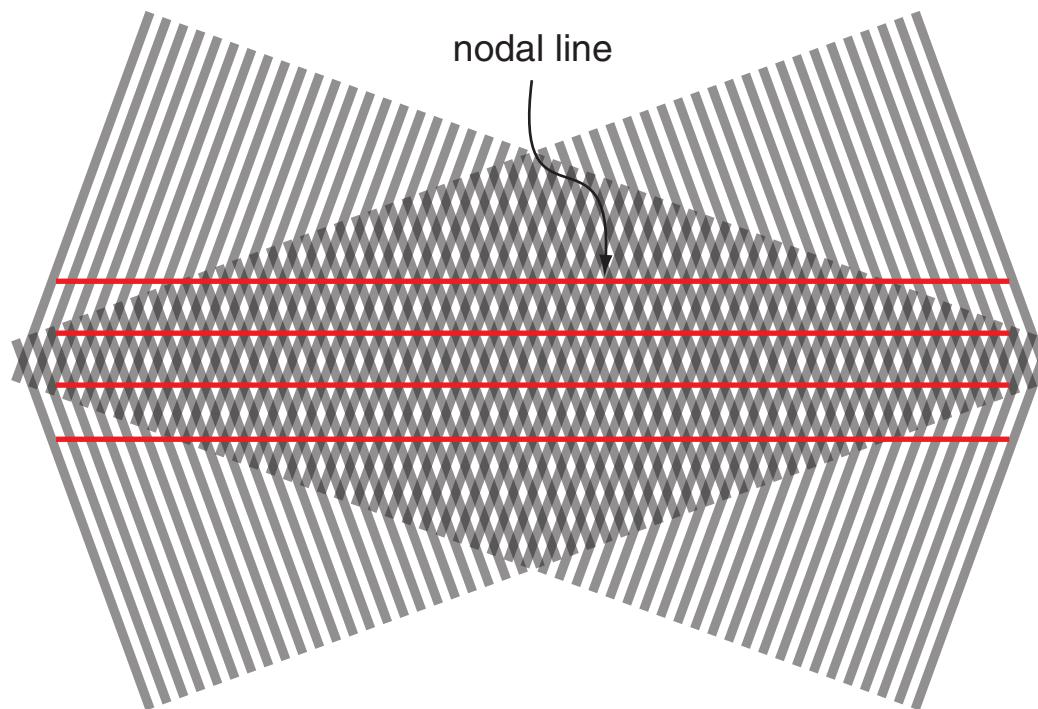
Waveguiding

...cause an interference pattern



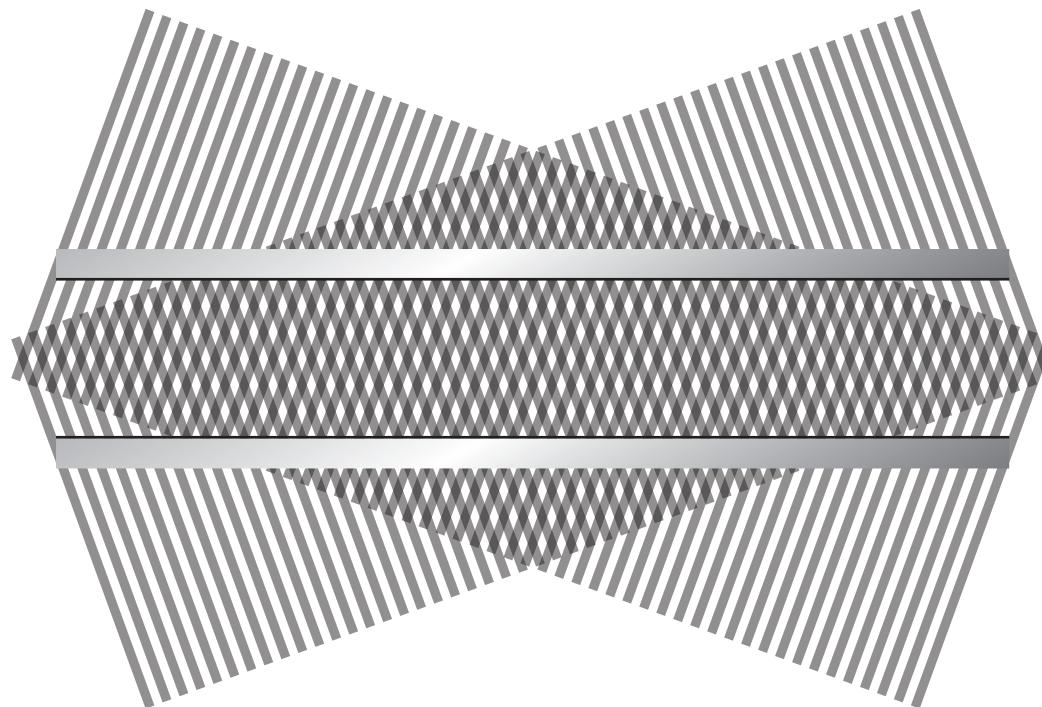
Waveguiding

$E = 0$ on the nodal lines



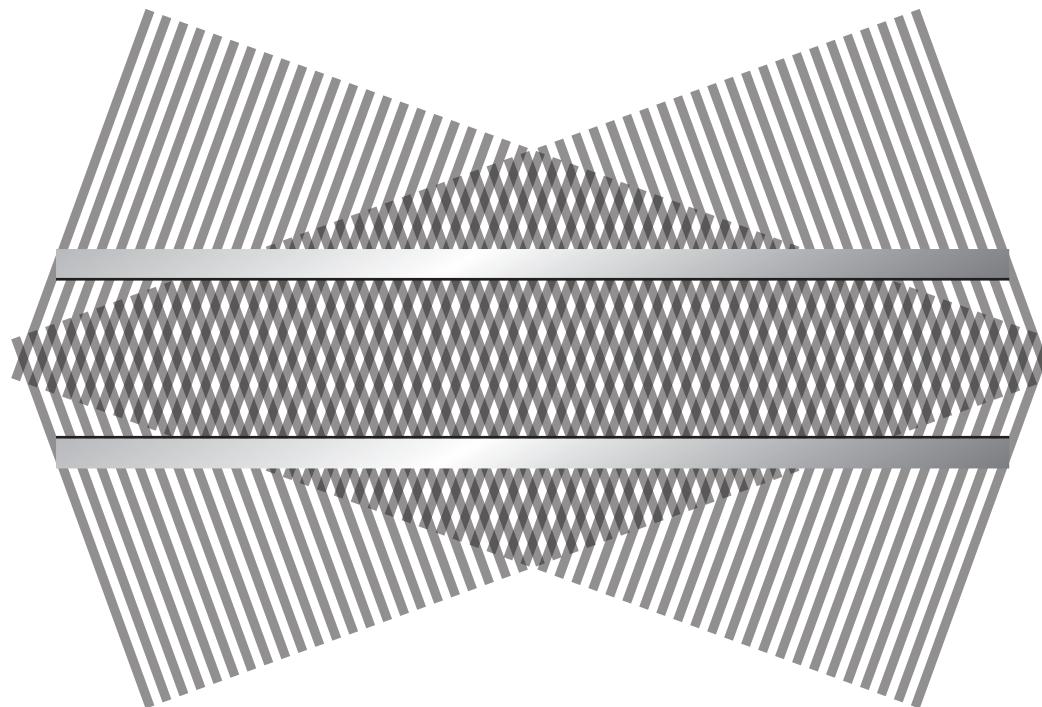
Waveguiding

...satisfying boundary conditions for planar-mirror waveguide



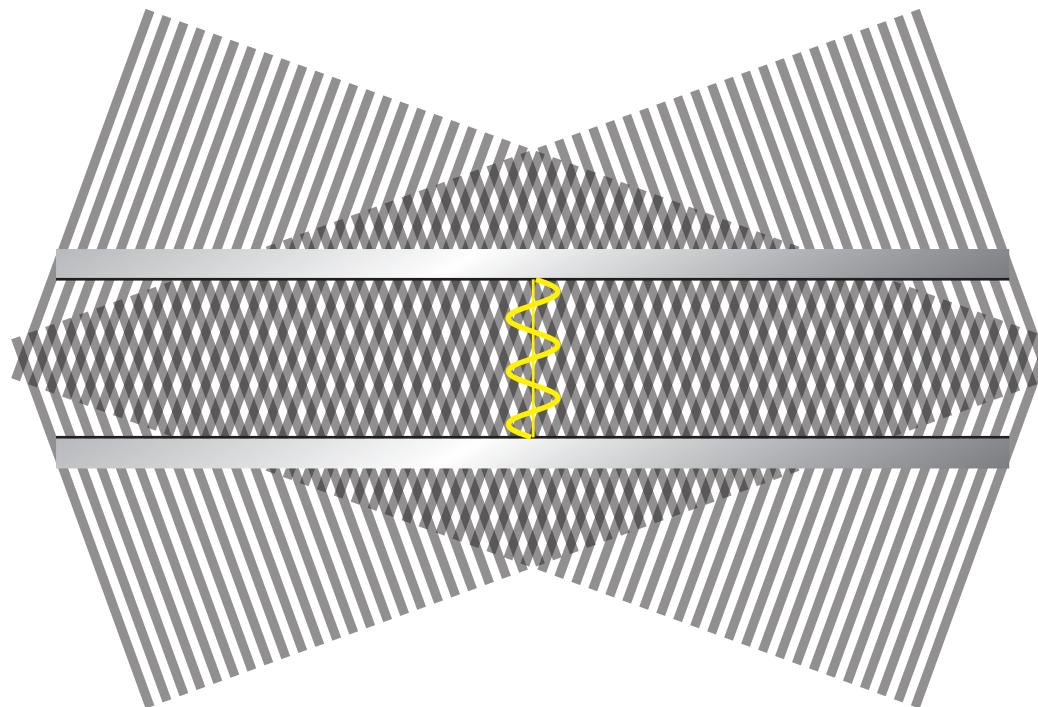
Waveguiding

transverse standing wave, traveling along axis



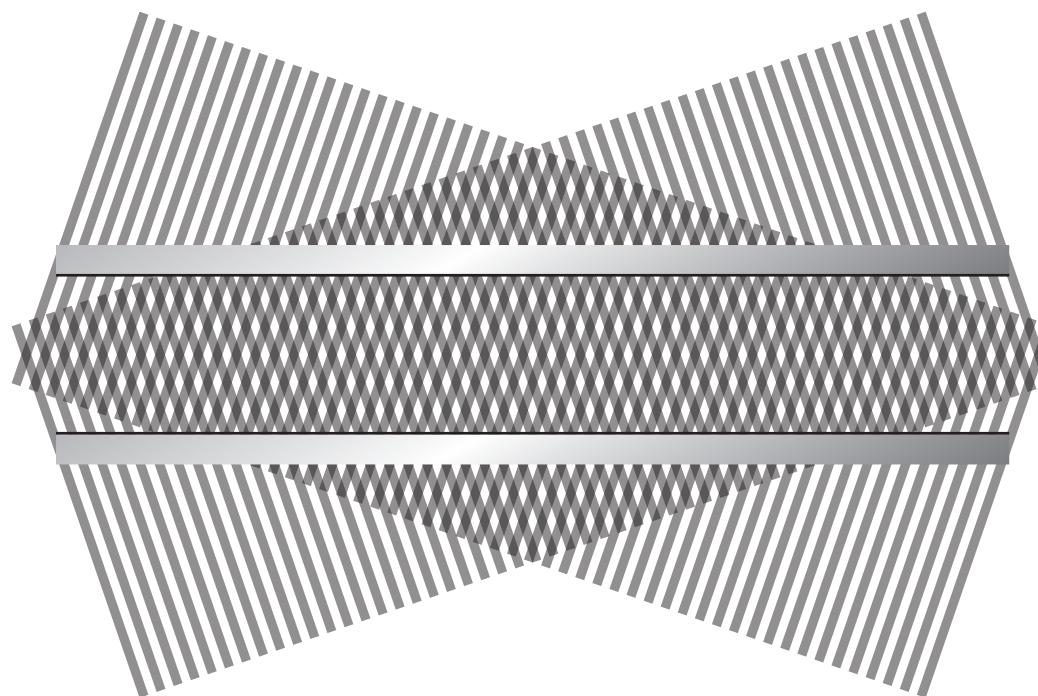
Waveguiding

transverse standing wave, traveling along axis



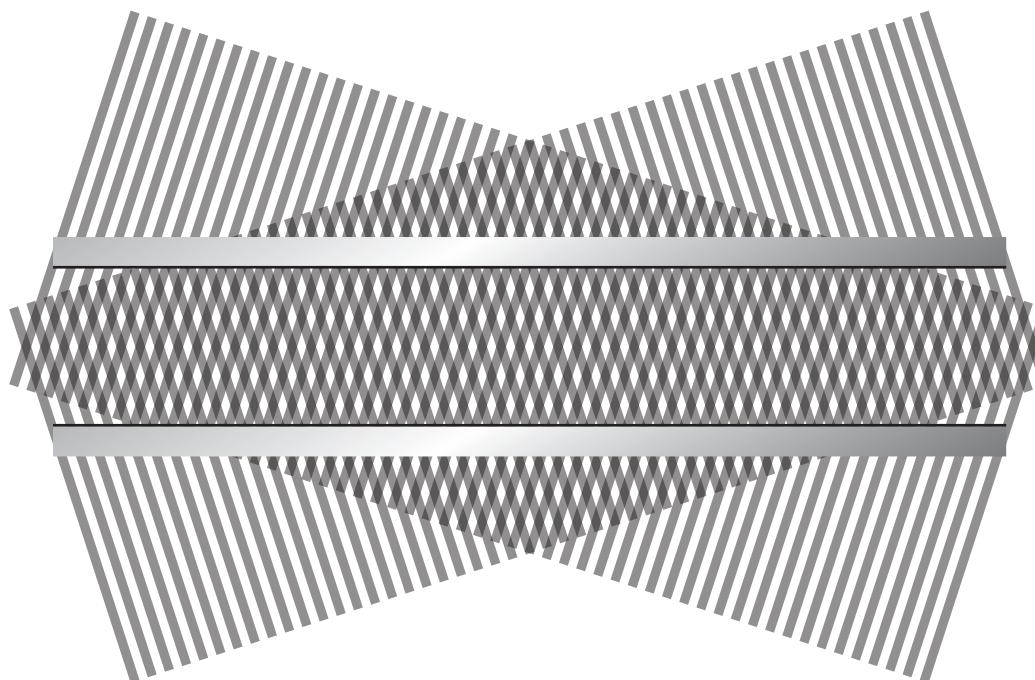
Waveguiding

change angle of incident waves...



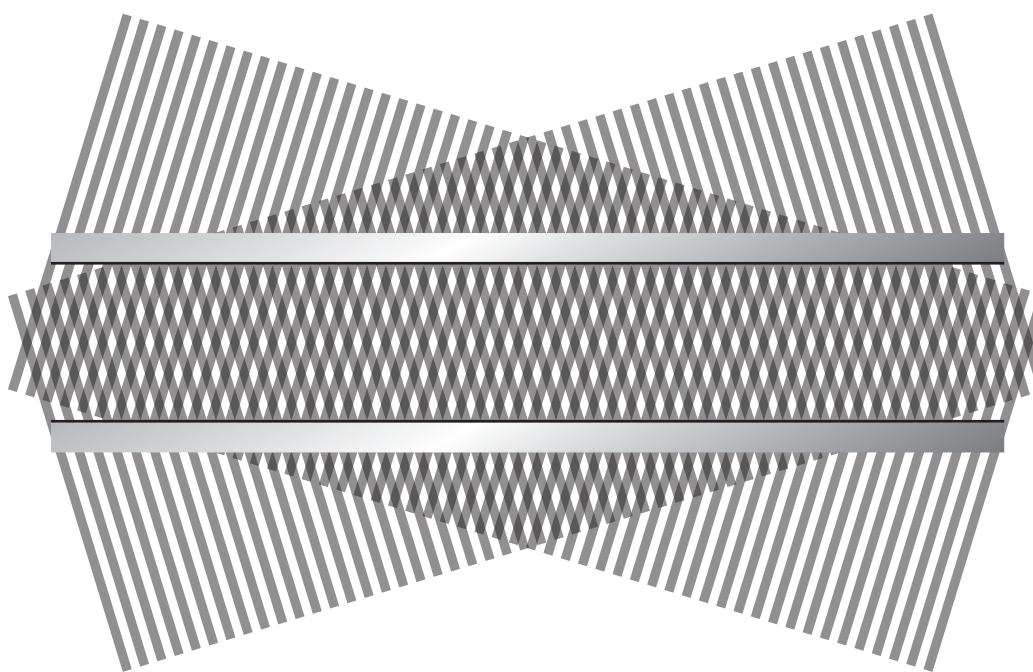
Waveguiding

change angle of incident waves...



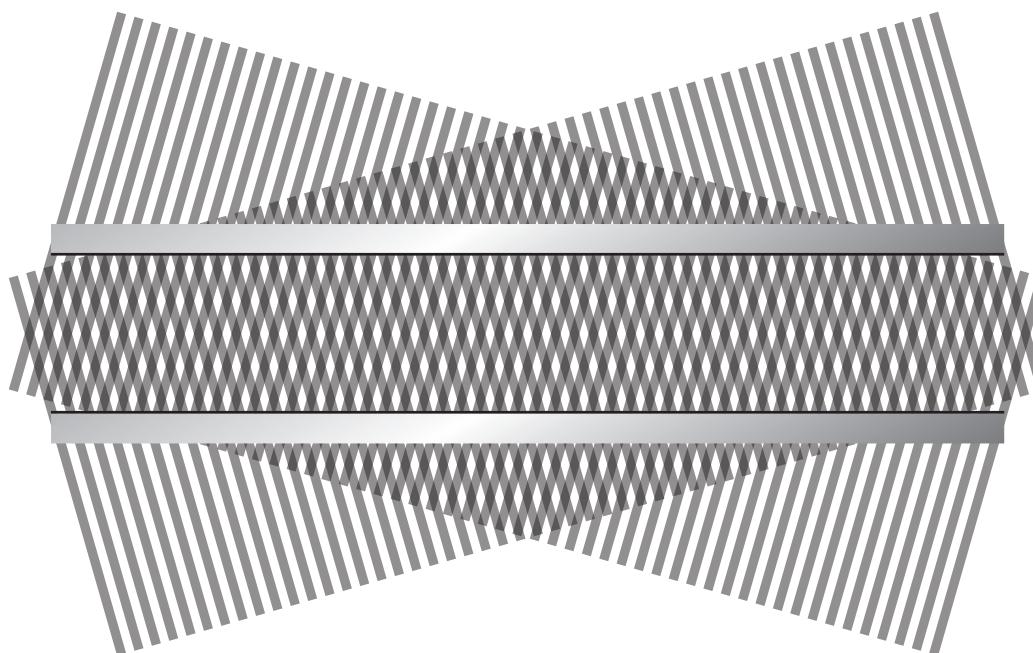
Waveguiding

change angle of incident waves...



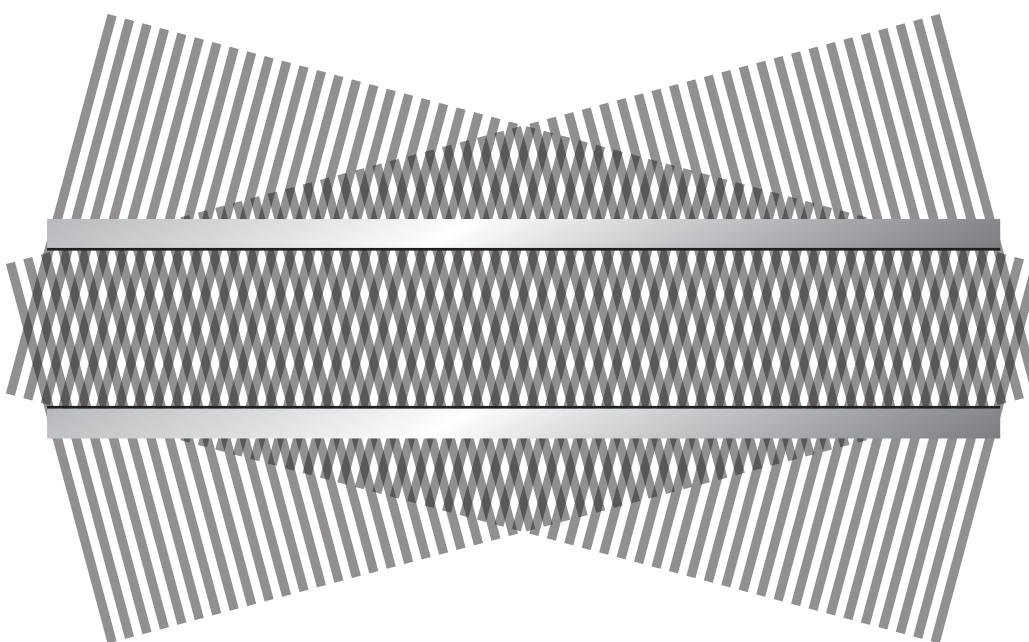
Waveguiding

change angle of incident waves...



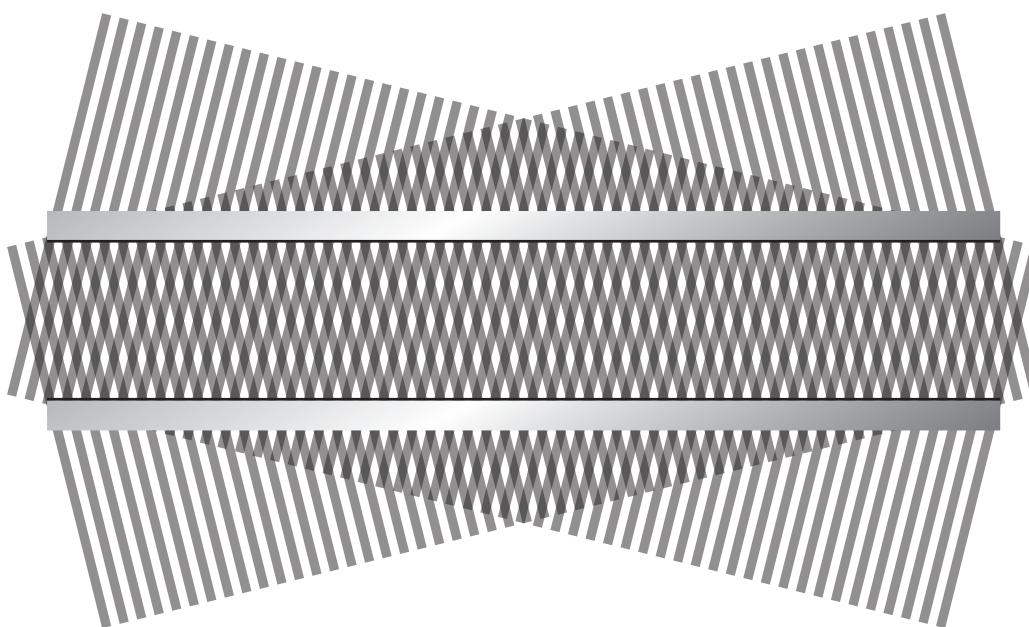
Waveguiding

change angle of incident waves...



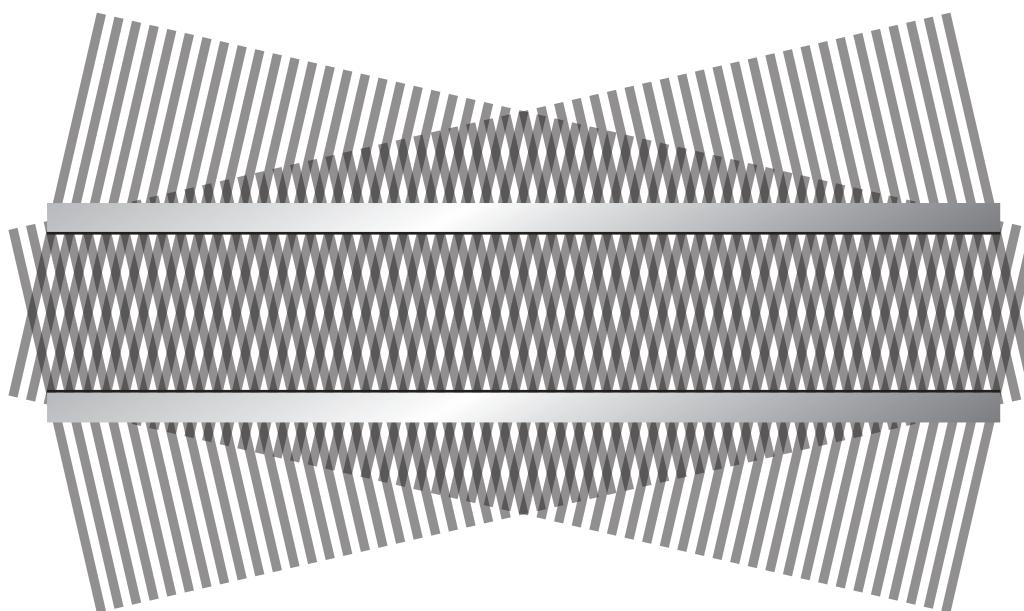
Waveguiding

change angle of incident waves...



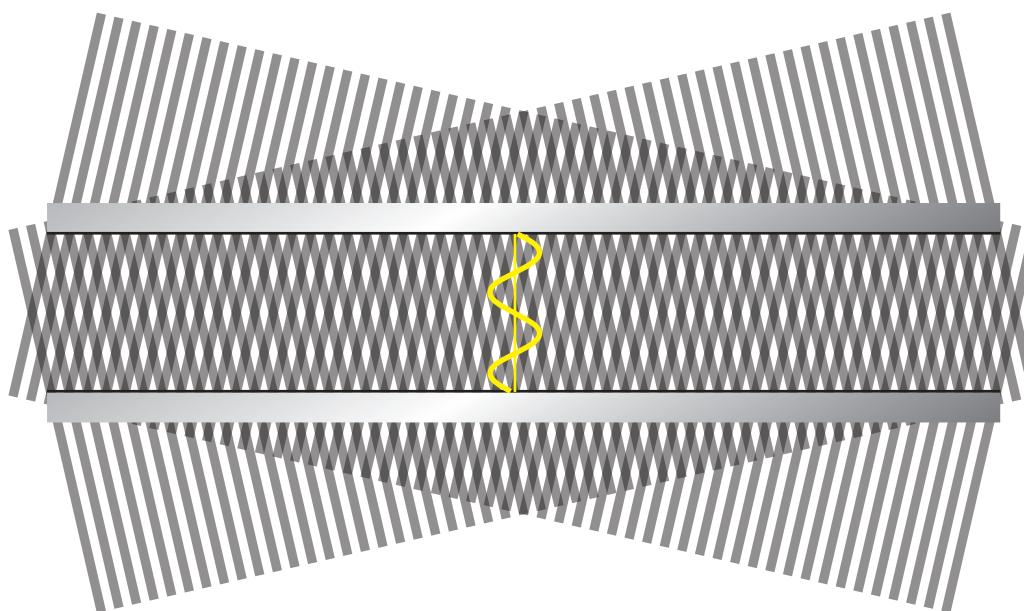
Waveguiding

change angle of incident waves...



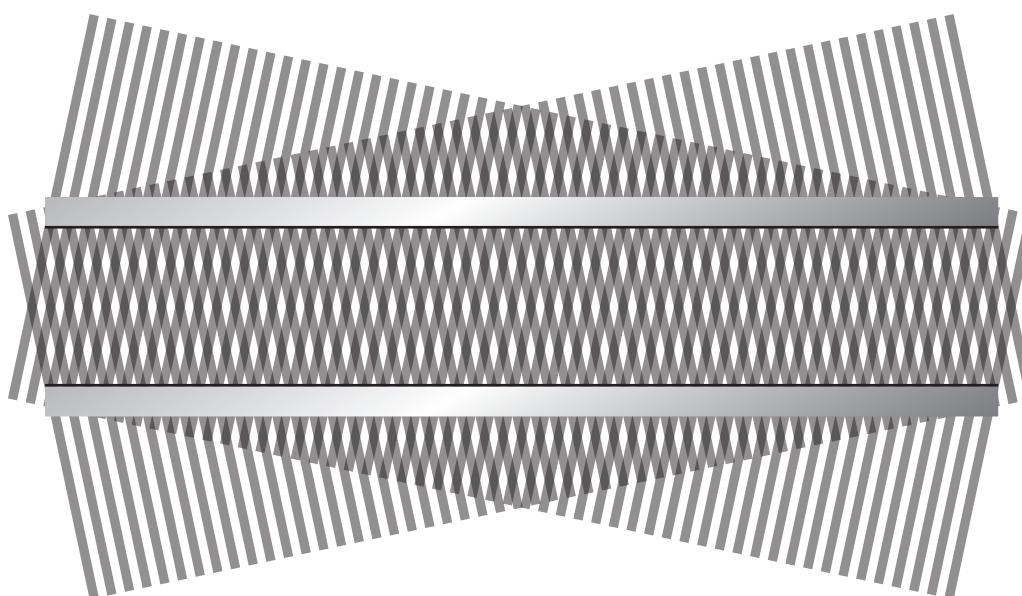
Waveguiding

change angle of incident waves...



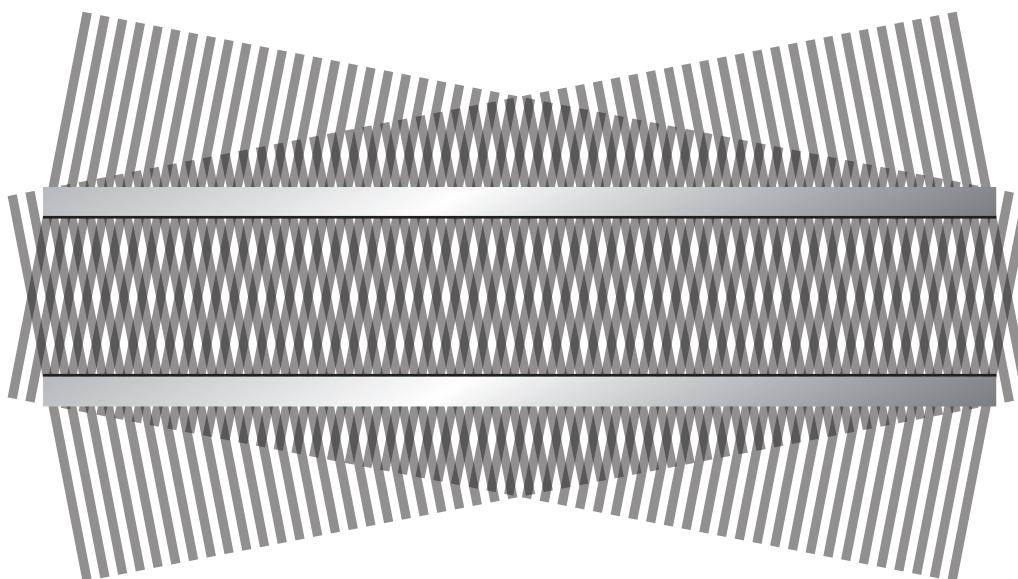
Waveguiding

change angle of incident waves...



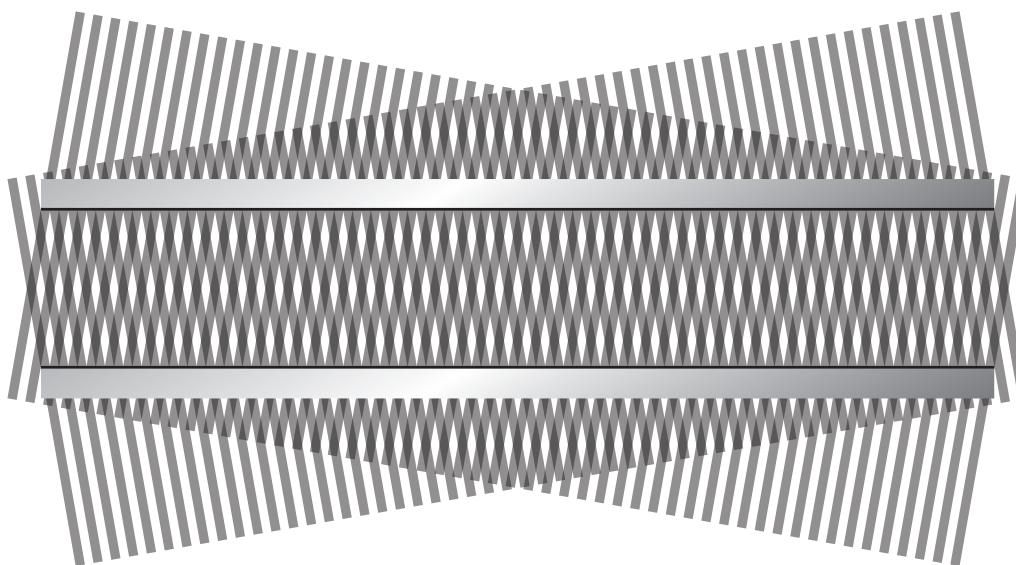
Waveguiding

change angle of incident waves...



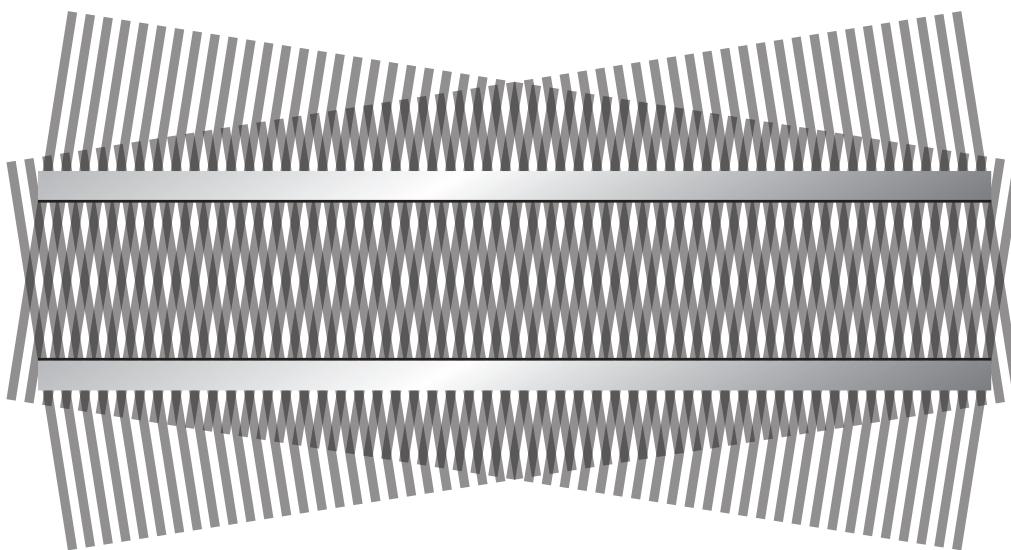
Waveguiding

change angle of incident waves...



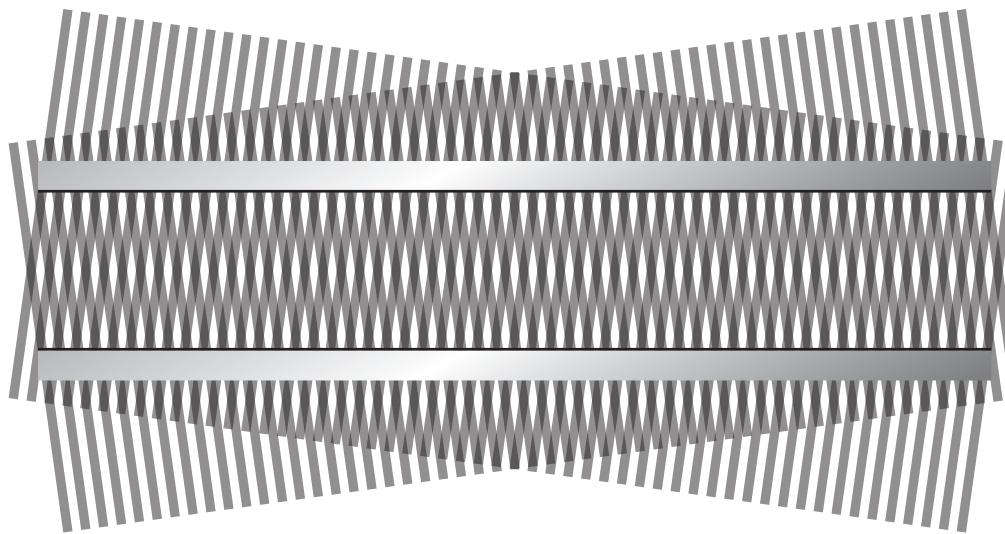
Waveguiding

change angle of incident waves...



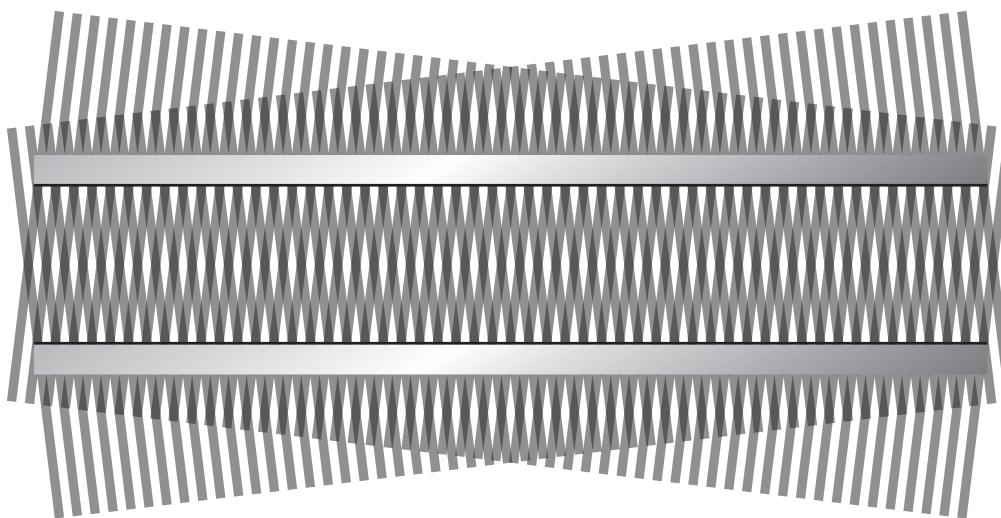
Waveguiding

change angle of incident waves...



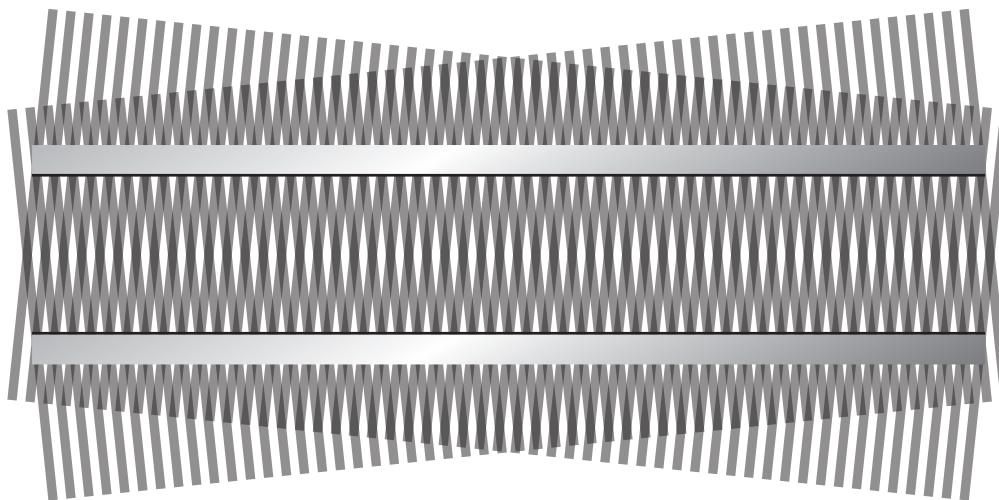
Waveguiding

change angle of incident waves...



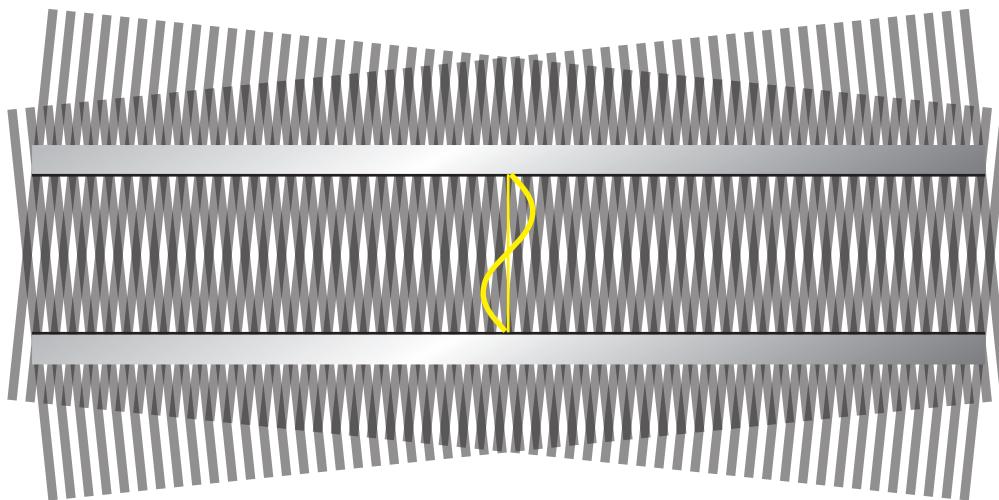
Waveguiding

change angle of incident waves...



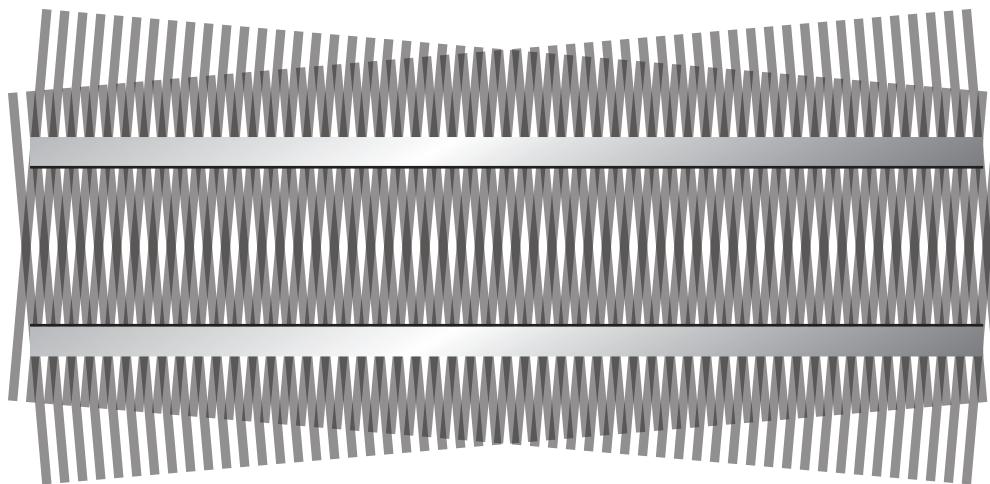
Waveguiding

change angle of incident waves...



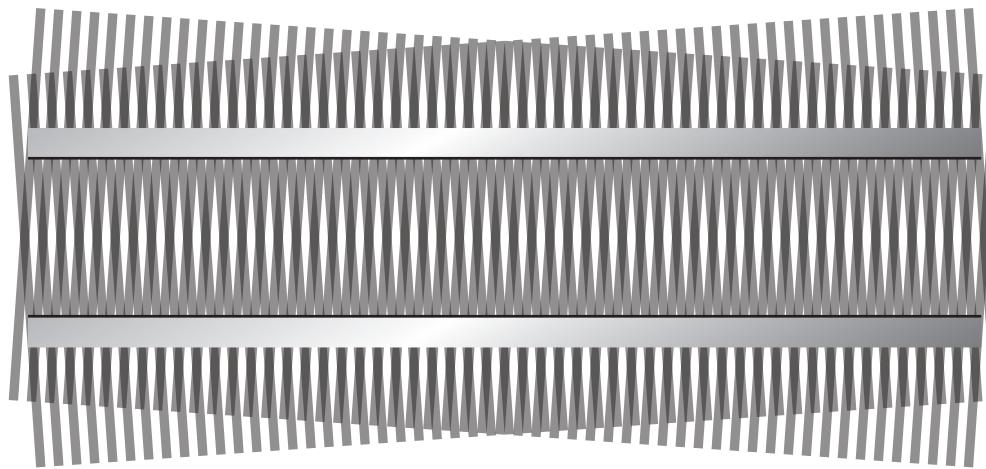
Waveguiding

change angle of incident waves...



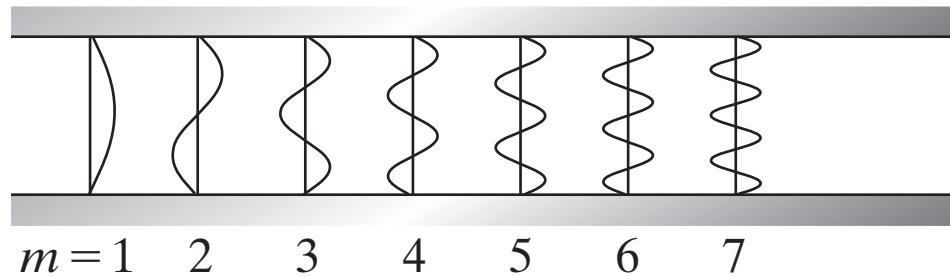
Waveguiding

change angle of incident waves...



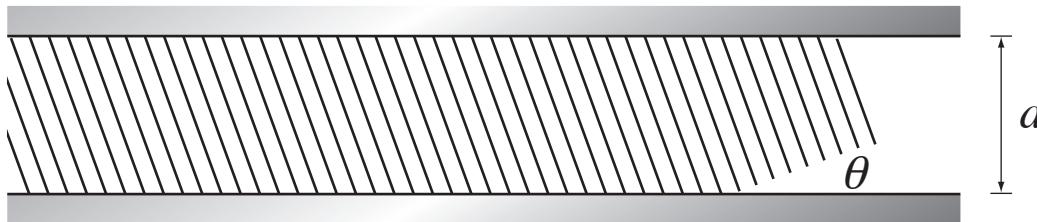
Waveguiding

boundary conditions only satisfied for certain θ



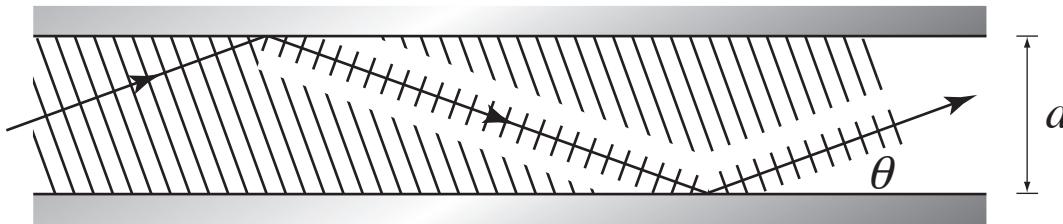
standing wave in y -direction, traveling in z -direction

Waveguiding



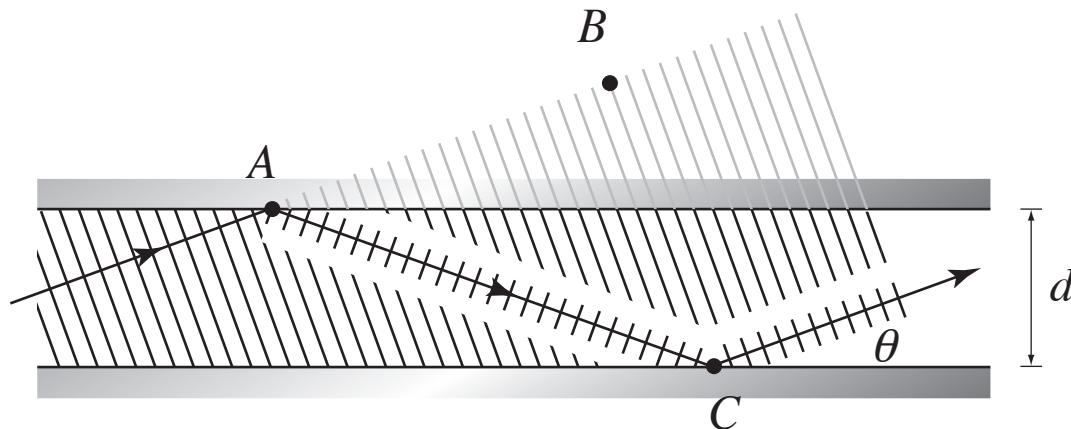
consider wave incident at angle θ

Waveguiding



twice-reflected wave

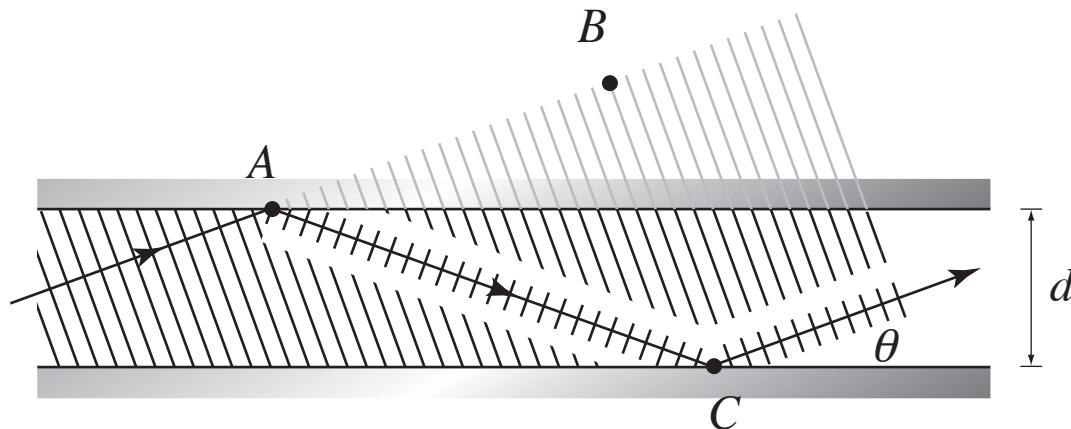
Waveguiding



self consistency:

$$AC - AB = 2d \sin \theta = m\lambda \quad (m = 1, 2, \dots)$$

Waveguiding



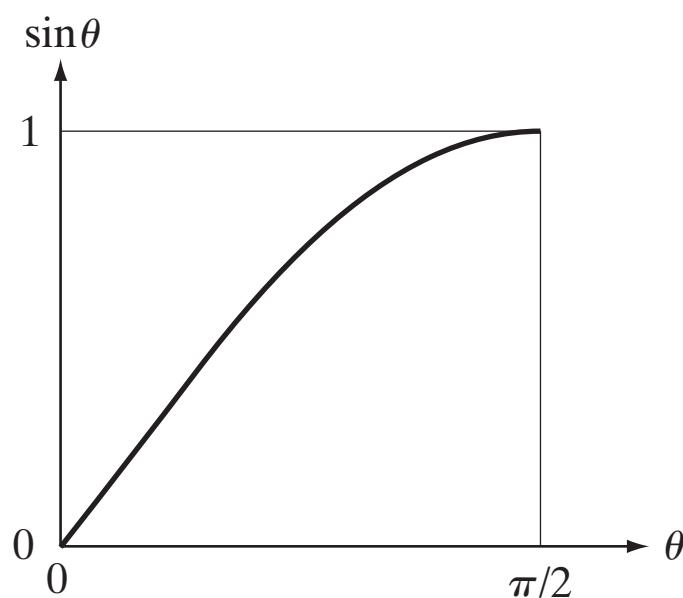
self consistency:

$$AC - AB = 2d \sin \theta = m\lambda \quad (m = 1, 2, \dots)$$

so:

$$\sin \theta_m = m \frac{\lambda}{2d}$$

Waveguiding



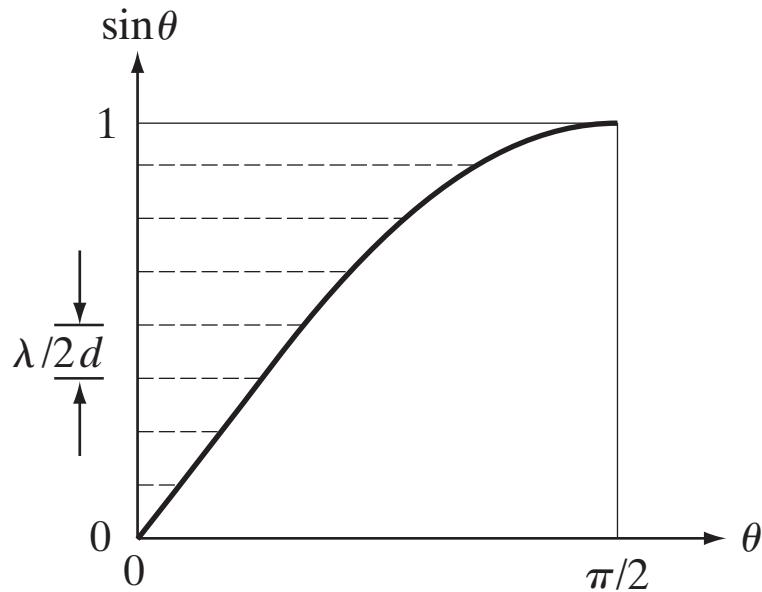
self consistency:

$$AC - AB = 2d \sin \theta = m\lambda \quad (m = 1, 2, \dots)$$

so:

$$\sin \theta_m = m \frac{\lambda}{2d}$$

Waveguiding



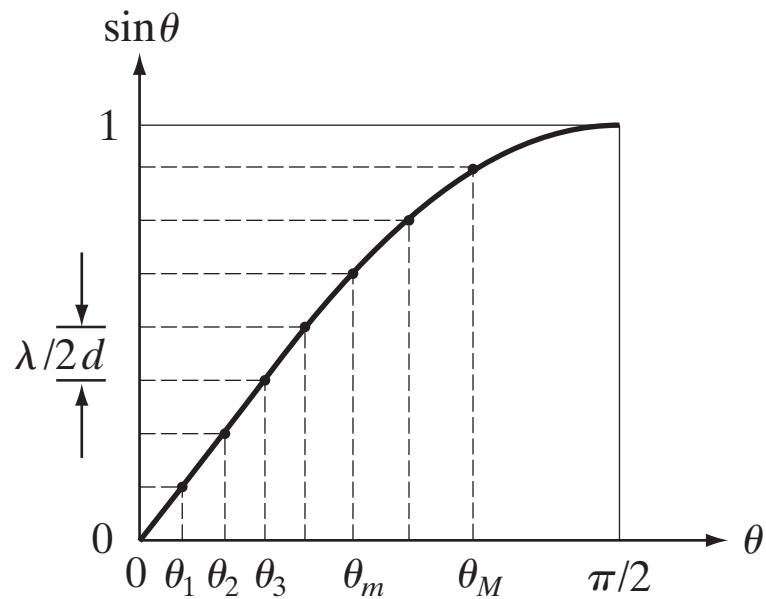
self consistency:

$$AC - AB = 2d \sin \theta = m\lambda \quad (m = 1, 2, \dots)$$

so:

$$\sin \theta_m = m \frac{\lambda}{2d}$$

Waveguiding



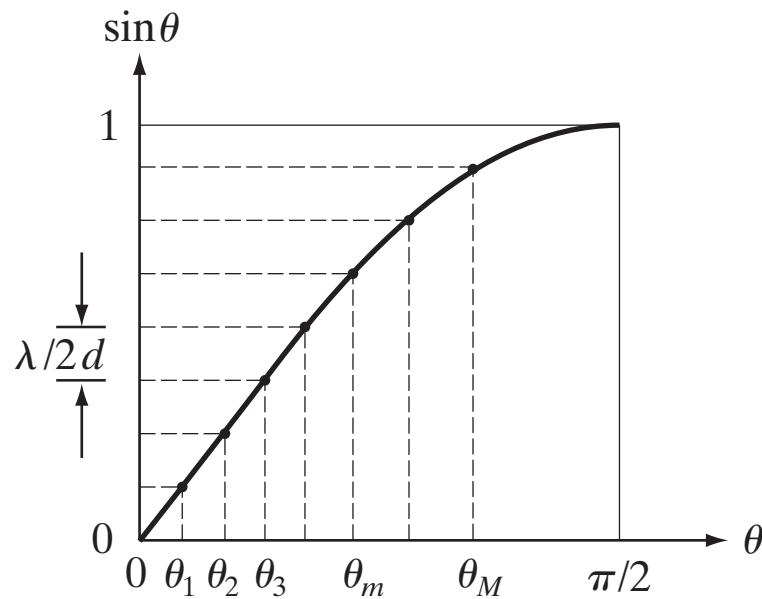
self consistency:

$$AC - AB = 2d \sin \theta = m\lambda \quad (m = 1, 2, \dots)$$

so:

$$\sin \theta_m = m \frac{\lambda}{2d}$$

Waveguiding



number of modes:

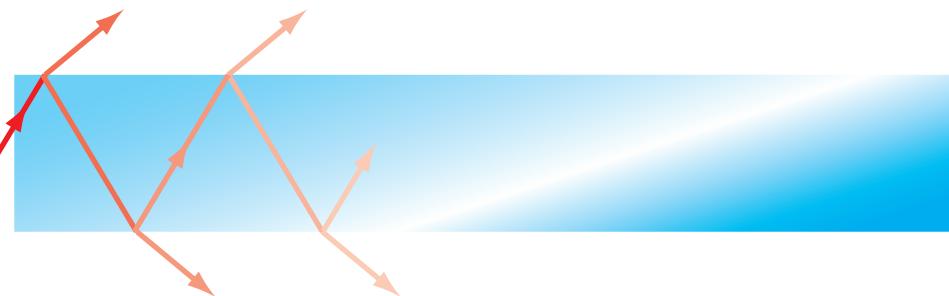
$$M \doteq \frac{2d}{\lambda}$$

Waveguiding



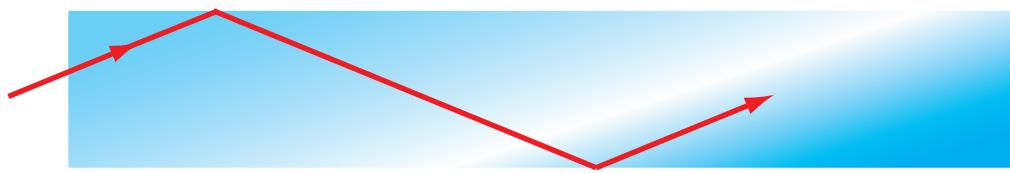
now consider a planar dielectric waveguide

Waveguiding



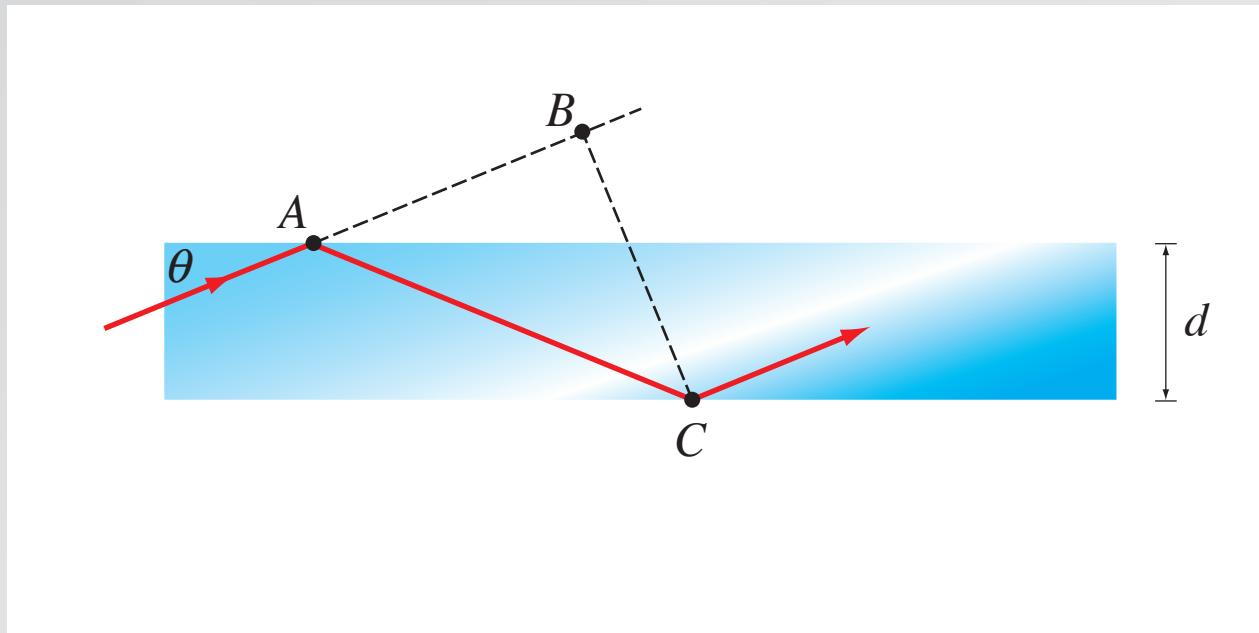
rays incident at angle $\theta > \pi/2 - \theta_c$ are unguided

Waveguiding



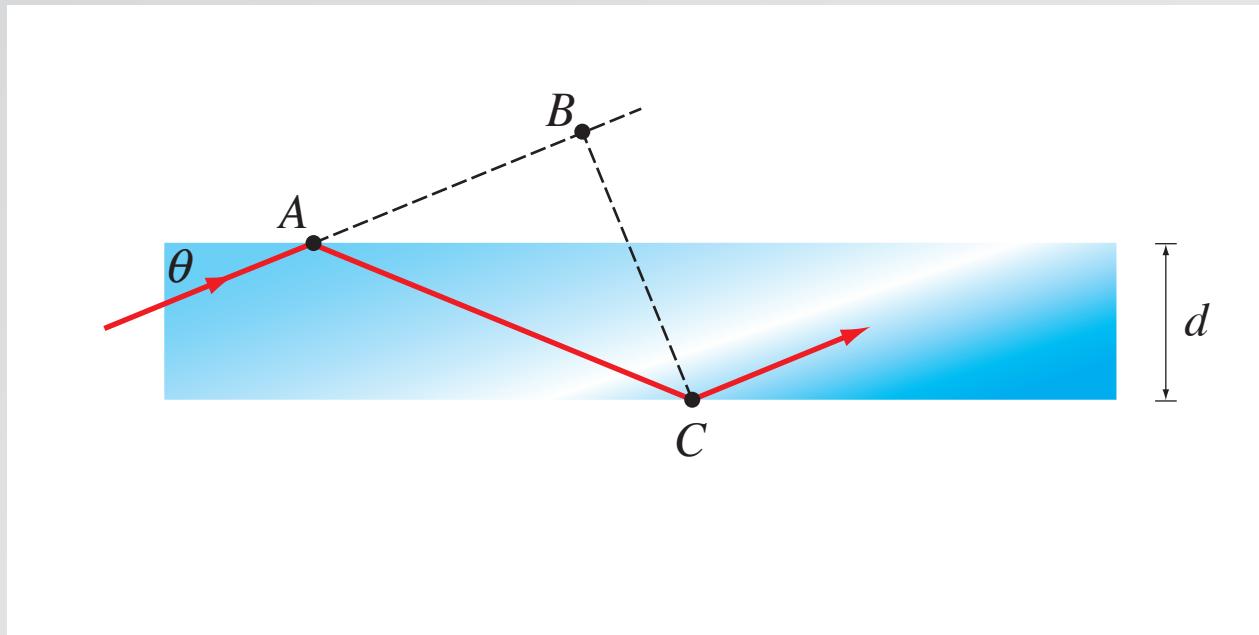
rays incident at angle $\theta < \pi/2 - \theta_c$ are guided

Waveguiding



rays incident at angle $\theta < \pi/2 - \theta_c$ are guided

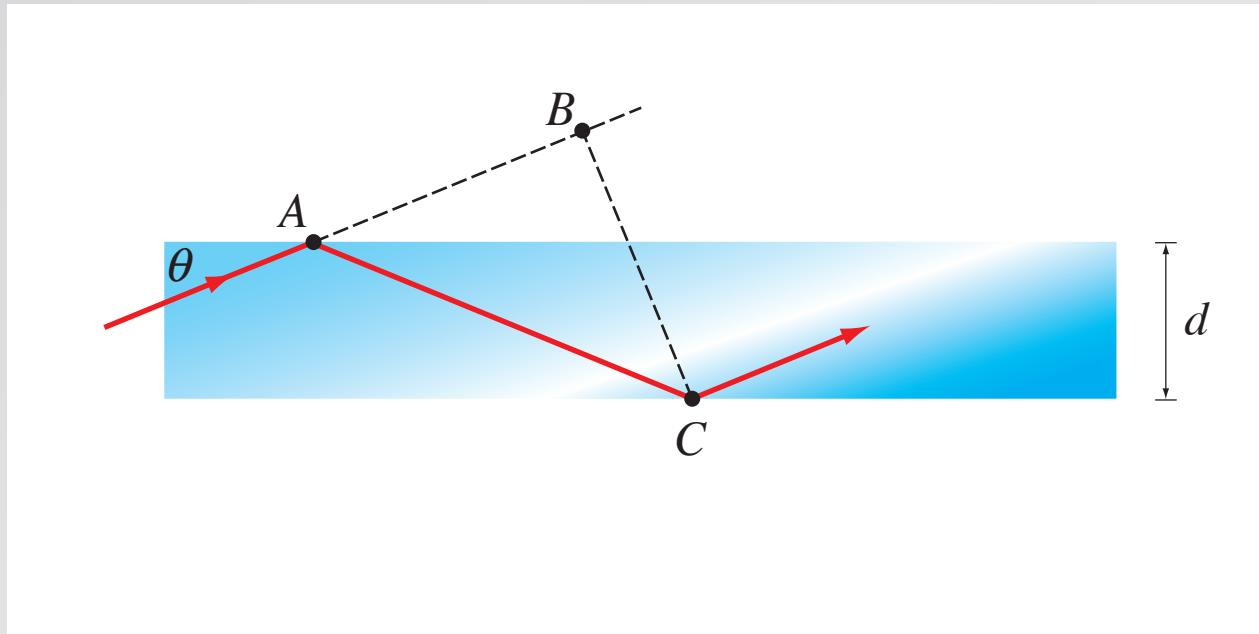
Waveguiding



self consistency:

$$AC - AB = 2d \sin \theta - \frac{\varphi_r}{\pi} \lambda = m\lambda \quad (m = 0, 1, 2\dots)$$

Waveguiding



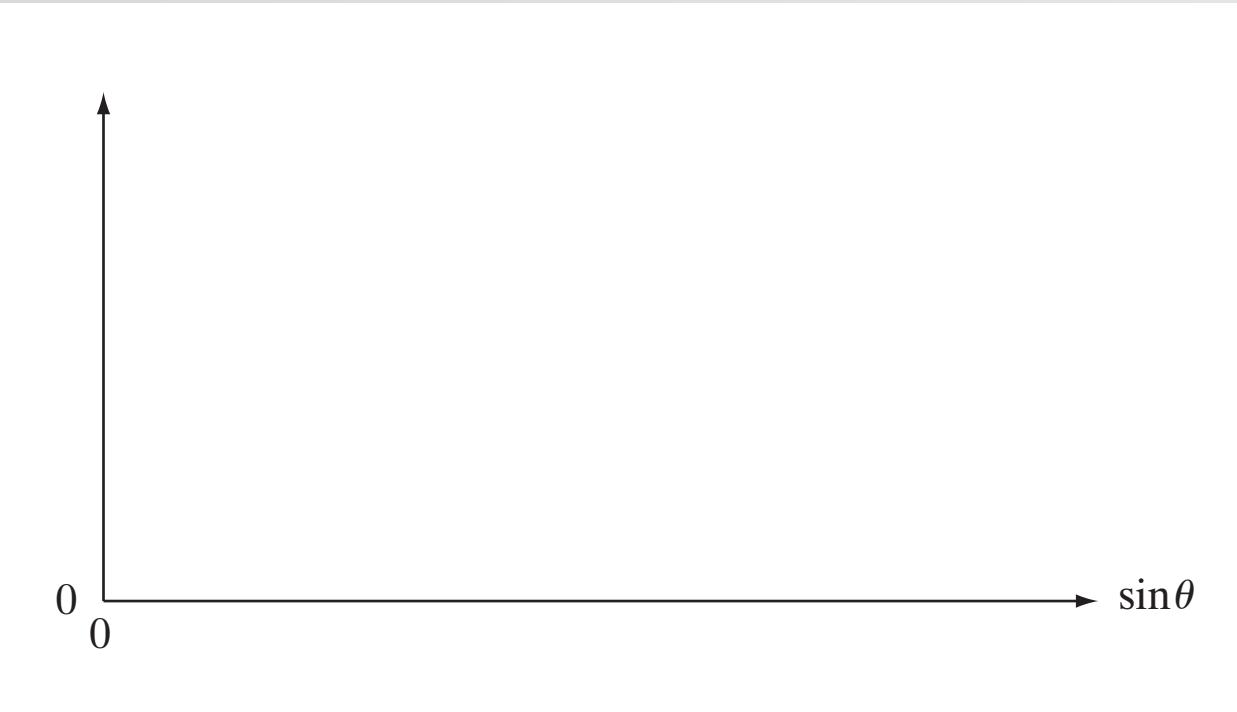
self consistency:

$$AC - AB = 2d \sin \theta - \frac{\varphi_r}{\pi} \lambda = m\lambda \quad (m = 0, 1, 2\dots)$$

so:

$$\tan\left(\frac{\pi d}{\lambda} \sin \theta - m \frac{\pi}{2}\right) = \left(\frac{\sin^2(\pi/2 - \theta_c)}{\sin^2 \theta} - 1\right)^{1/2}$$

Waveguiding



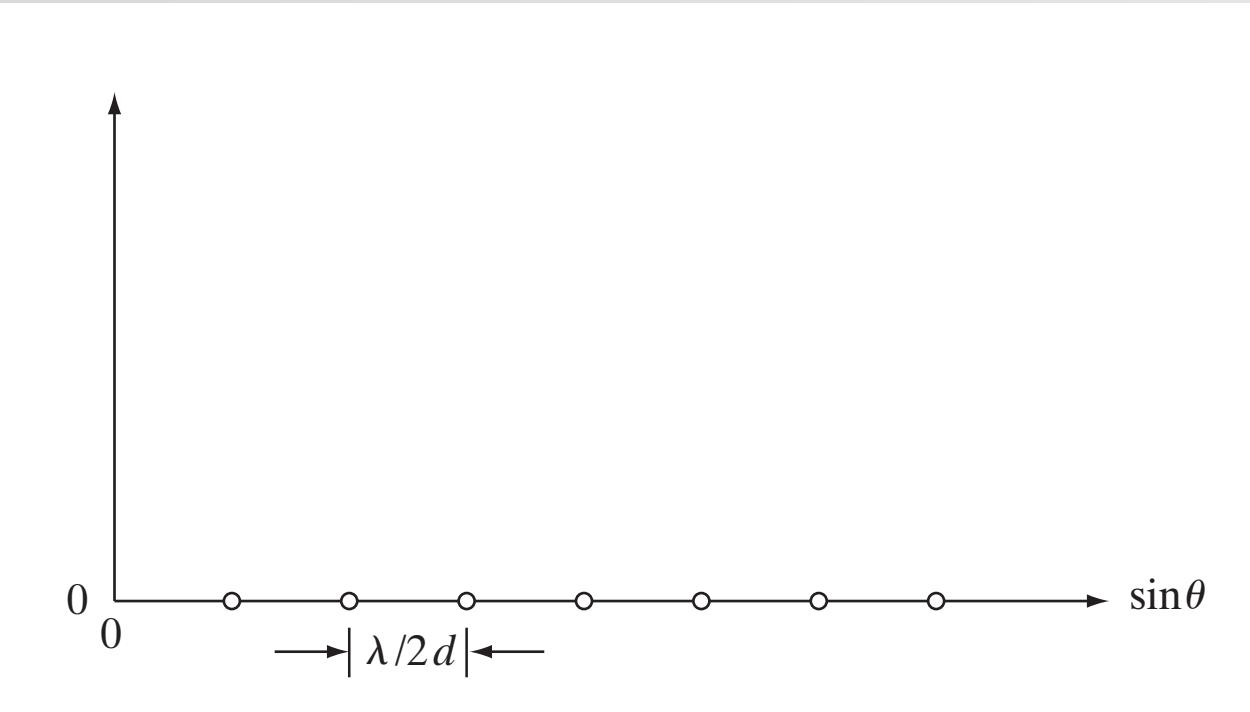
self consistency:

$$AC - AB = 2d \sin\theta - \frac{\varphi_r}{\pi}\lambda = m\lambda \quad (m = 0, 1, 2\dots)$$

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Waveguiding



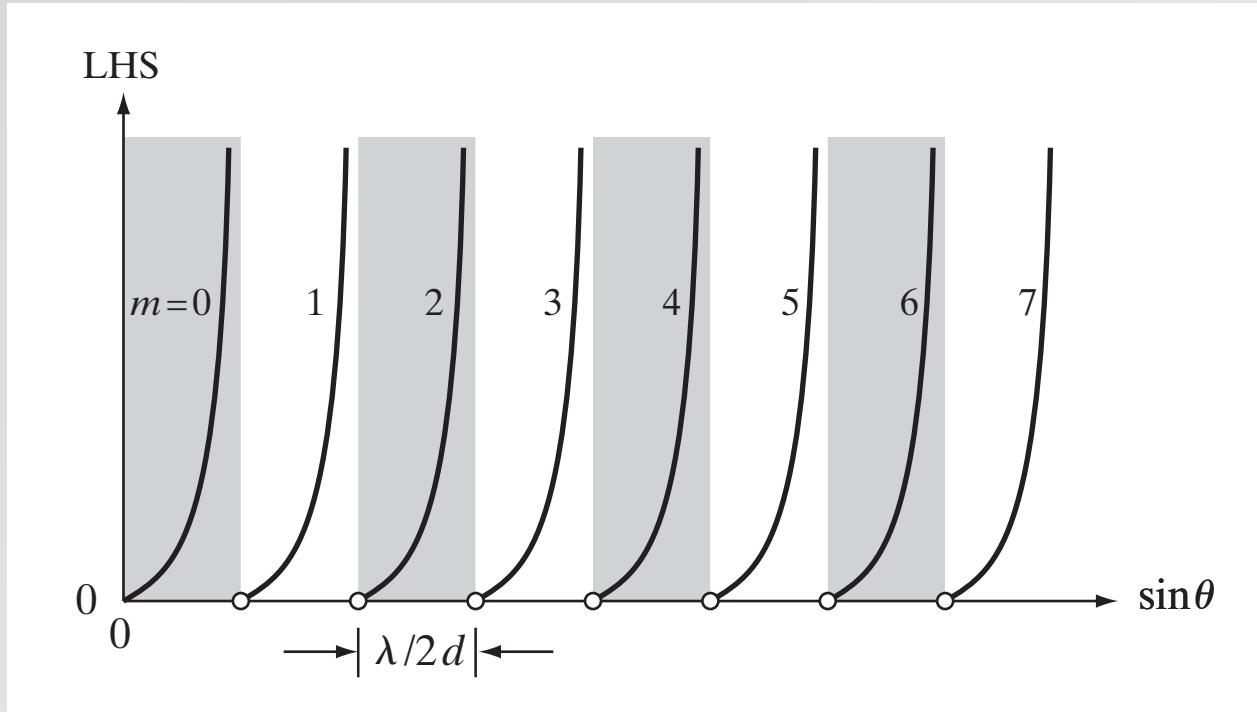
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$$AC - AB = 2d \sin \theta - \frac{\varphi_r}{\pi} \lambda = m\lambda \quad (m = 0, 1, 2\dots)$$

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Waveguiding



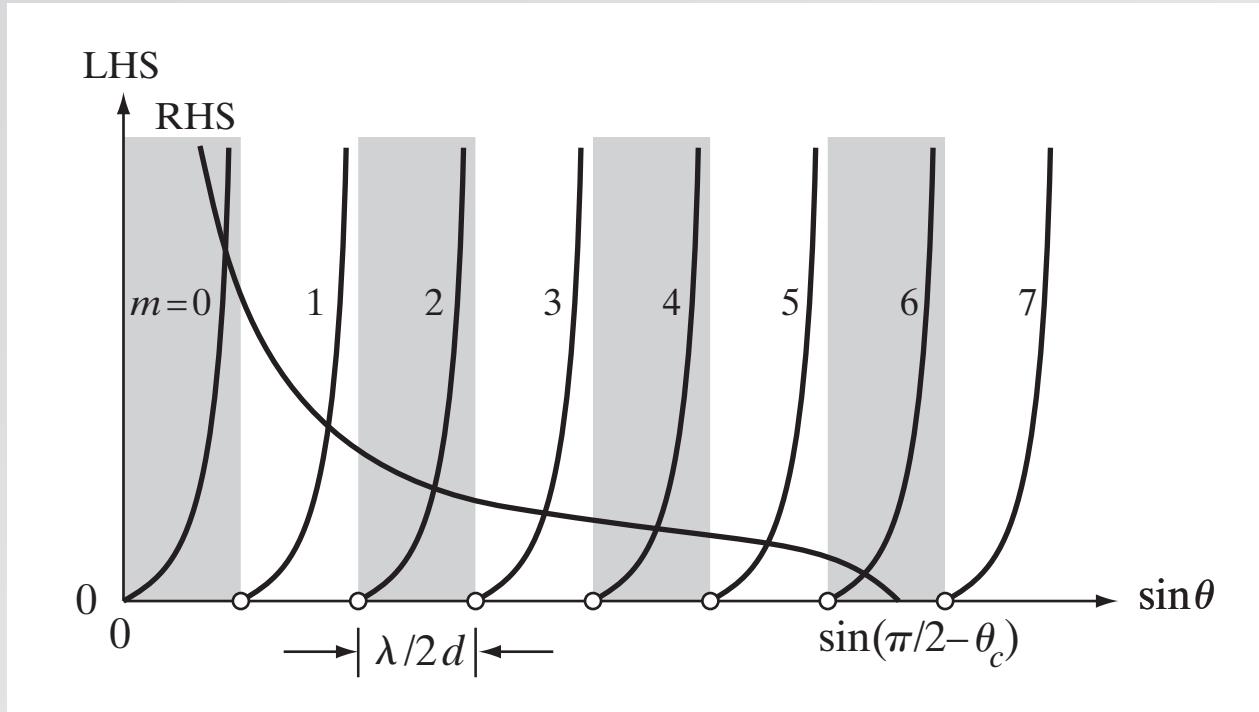
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Waveguiding



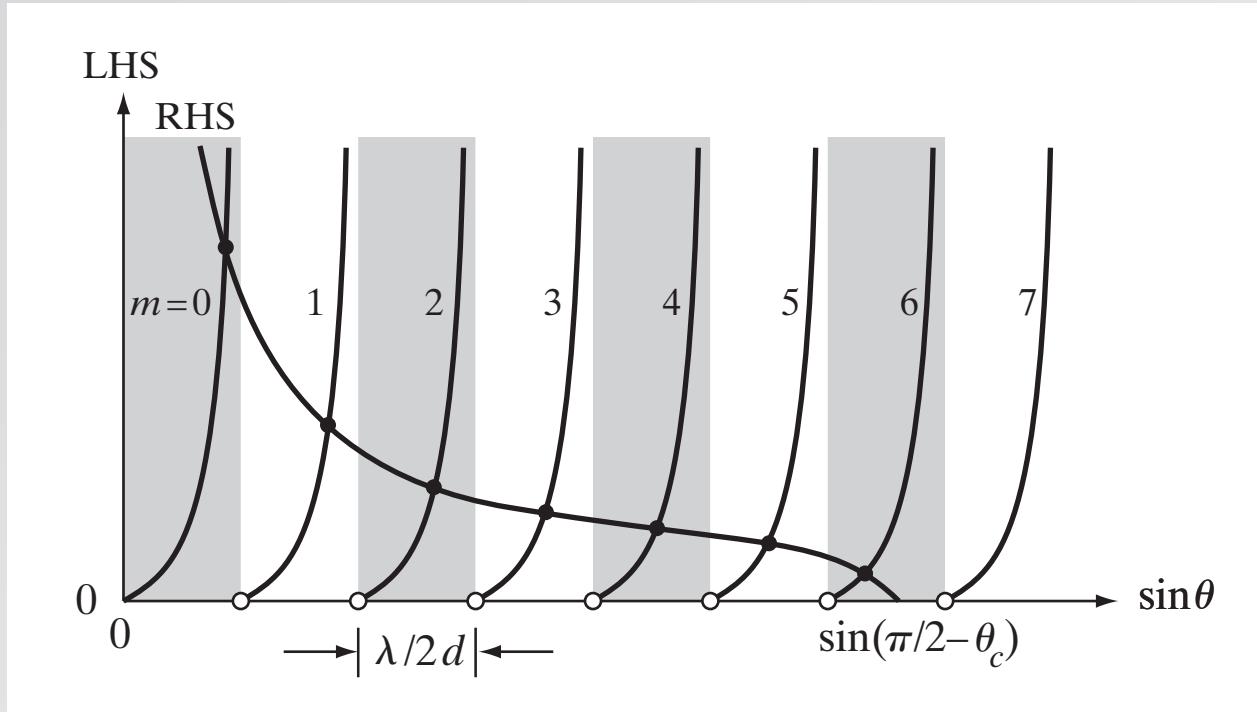
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Waveguiding



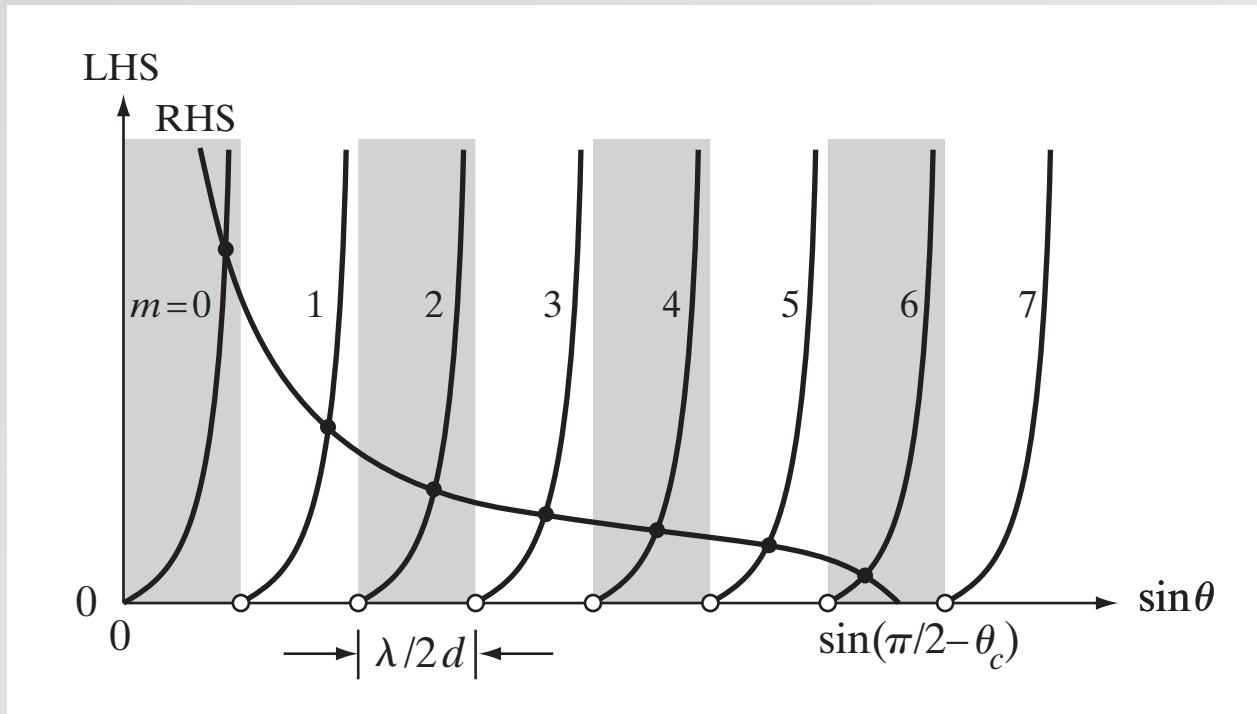
self consistency:

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$$\tan\left(\frac{\pi d}{\lambda} \sin \theta - m \frac{\pi}{2}\right) = \left(\frac{\sin^2(\pi/2 - \theta_c)}{\sin^2 \theta} - 1\right)^{1/2}$$

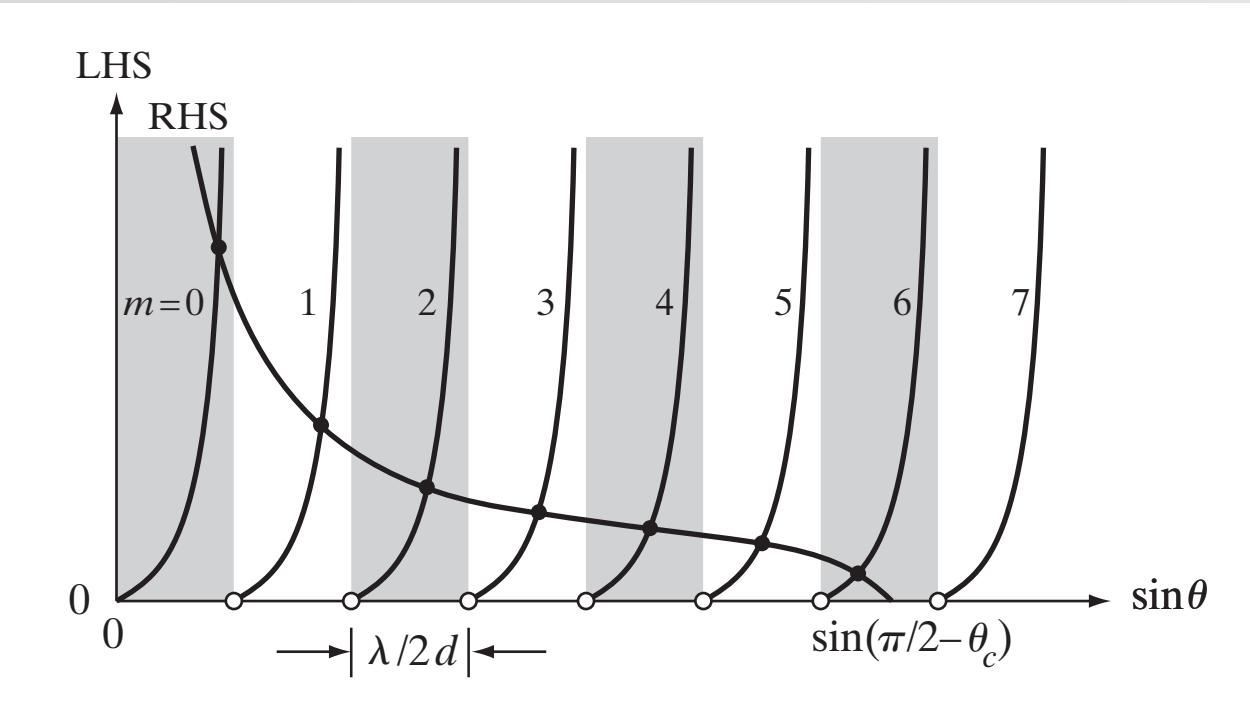
Waveguiding



number of modes:

$$M \doteq \frac{\sin(\pi/2 - \theta_c)}{\lambda/2d}$$

Waveguiding



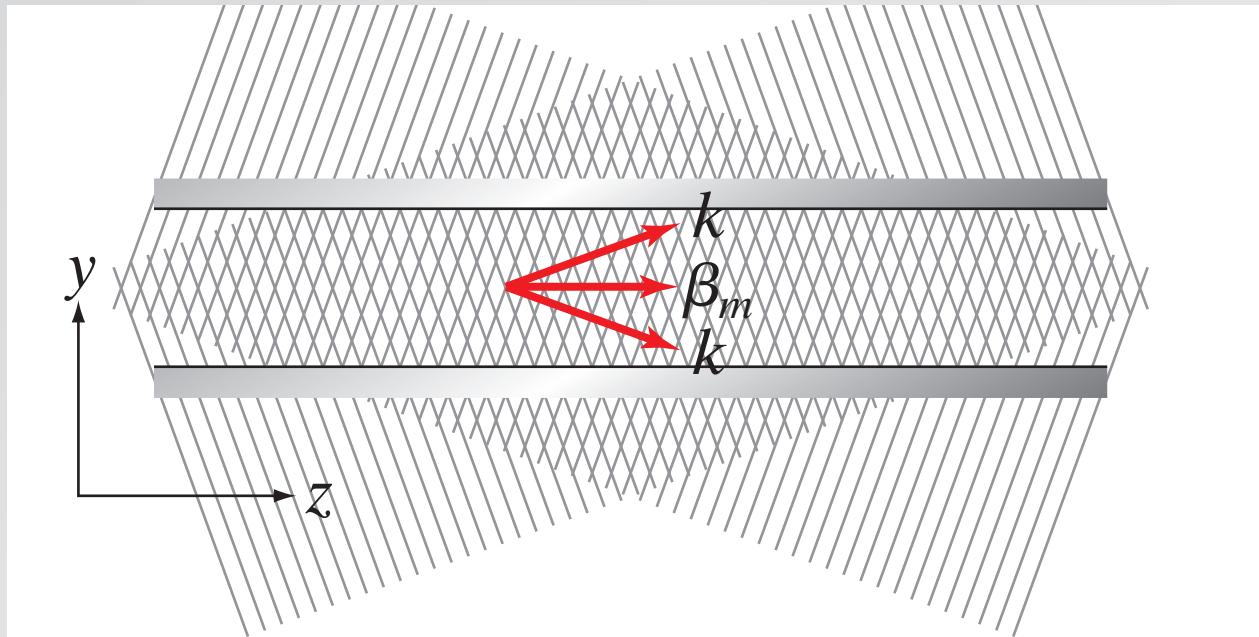
number of modes:

$$M \doteq \frac{\sin(\pi/2 - \theta_c)}{\lambda/2d}$$

or:

$$M \doteq 2 \frac{d}{\lambda} (n_1^2 - n_2^2)^{1/2}$$

Waveguiding



propagation constant of guided wave:

$$\beta_m^2 = k^2 - k_y^2 = k^2 - \frac{m^2 \pi^2}{d^2}$$

group velocity:

$$v_m = c \cos \theta_m$$

Waveguiding

single mode condition for 600-nm light:

planar mirror

$$M \doteq \frac{2d}{\lambda} \quad 300 < d < 600 \text{ nm}$$

dielectric

$$M \doteq 2 \frac{d}{\lambda} (n_1^2 - n_2^2)^{1/2} \quad d < 268 \text{ nm}$$

Waveguiding

single mode condition for 600-nm light:

planar mirror

$$M \doteq \frac{2d}{\lambda} \quad 300 < d < 600 \text{ nm}$$

dielectric

$$M \doteq 2 \frac{d}{\lambda} (n_1^2 - n_2^2)^{1/2} \quad d < 268 \text{ nm}$$

can make d larger by making $n_1 - n_2$ smaller!

Waveguiding

Vector potential obeys:

$$\nabla^2 \vec{A} + \omega^2 \mu_0 \epsilon \vec{A} = -i\omega \mu_0 \nabla \epsilon \Phi$$

Waveguiding

Vector potential obeys:

$$\nabla^2 \vec{A} + \omega^2 \mu_o \epsilon \vec{A} = 0$$

Waveguiding

Vector potential obeys:

$$\nabla^2 \vec{A} + \omega^2 \mu_0 \epsilon \vec{A} = 0$$

Substituting

$$\vec{A} = \hat{y} u(x,y) e^{-i\beta z}$$

Waveguiding

Vector potential obeys:

$$\nabla^2 \vec{A} + \omega^2 \mu_o \epsilon \vec{A} = 0$$

Substituting

$$\vec{A} = \hat{y} u(x, y) e^{-i\beta z}$$

yields:

$$\nabla_T^2 u + [-\beta^2 + \omega^2 \mu \epsilon(r)] u = 0$$

Waveguiding

Vector potential obeys:

$$\nabla^2 \vec{A} + \omega^2 \mu_o \epsilon \vec{A} = 0$$

Substituting

$$\vec{A} = \hat{y} u(x, y) e^{-i\beta z}$$

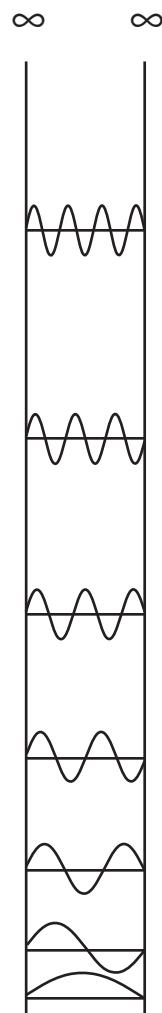
yields:

$$\nabla_T^2 u + [-\beta^2 + \omega^2 \mu \epsilon(r)] u = 0$$

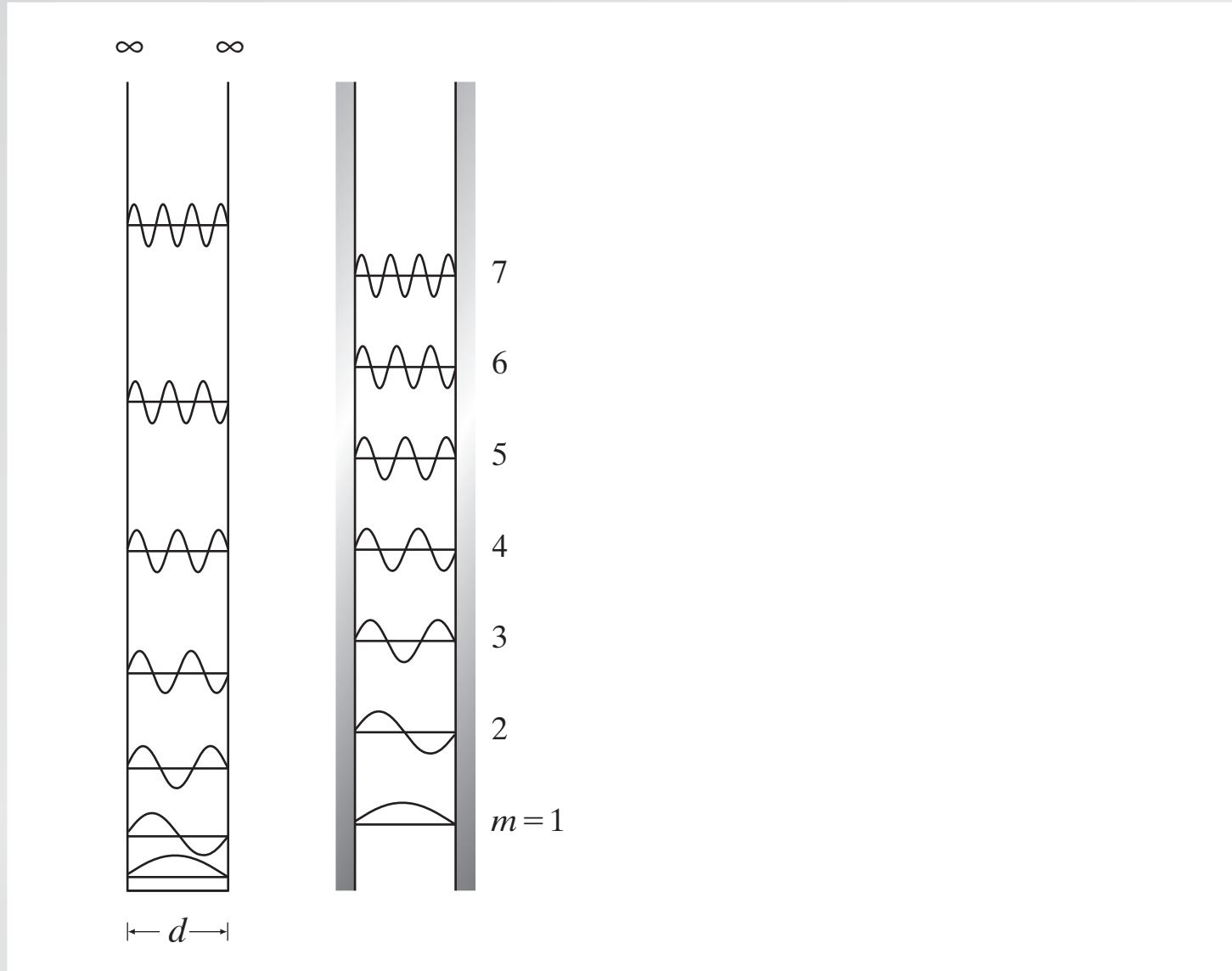
Compare to time-independent Schrödinger equation:

$$\nabla^2 \psi + \frac{2m}{\hbar^2} [E - V(r)] \psi = 0$$

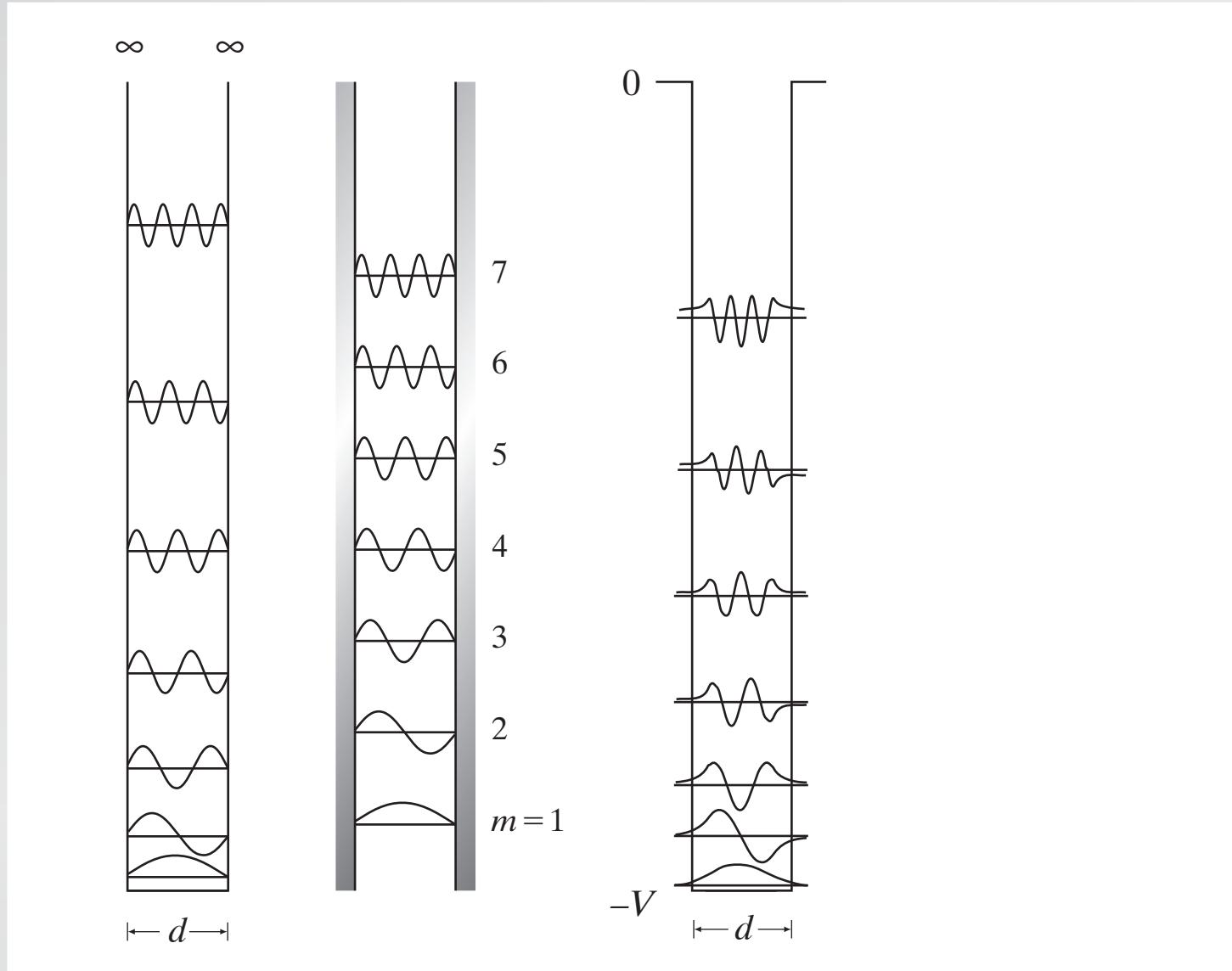
Waveguiding



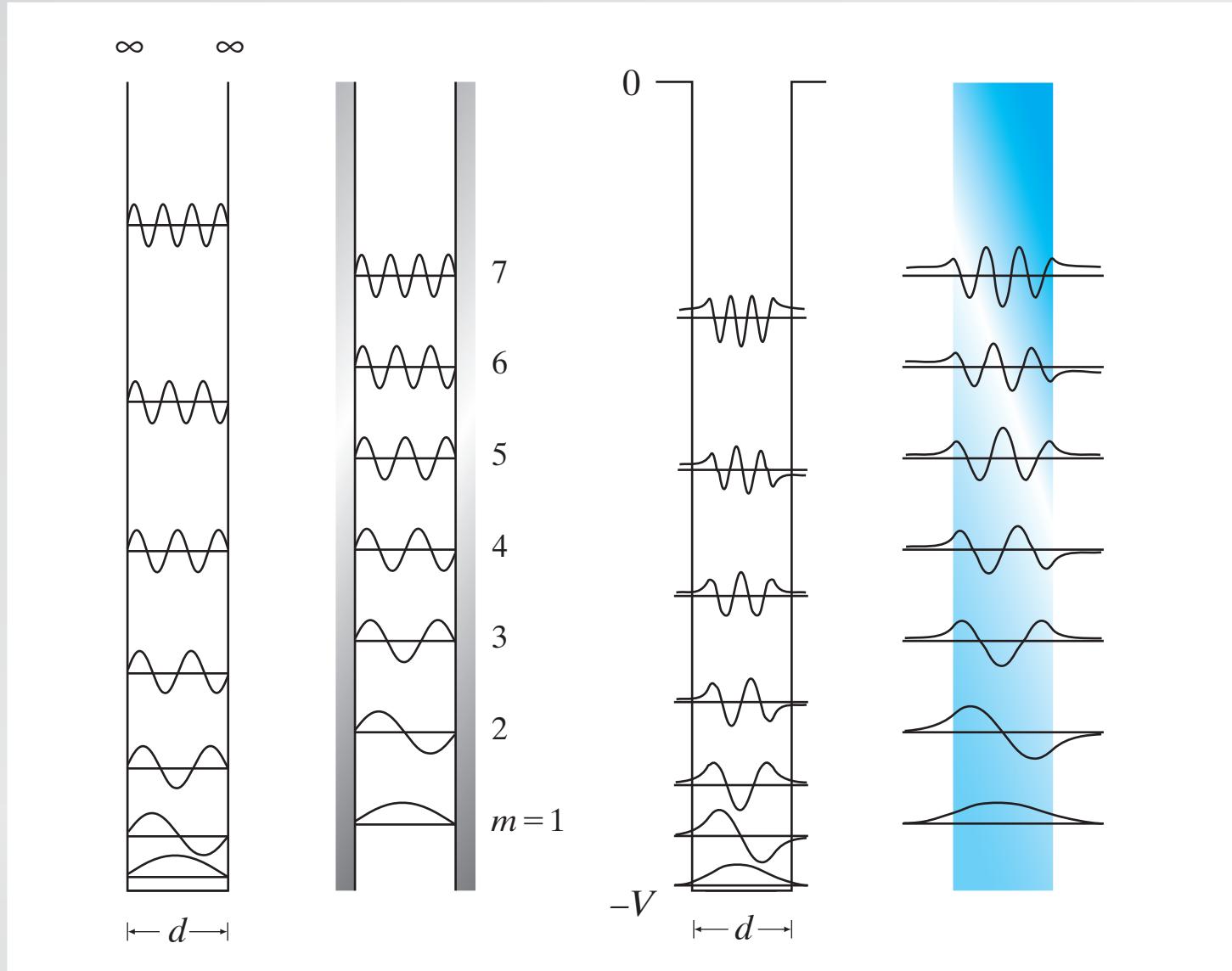
Waveguiding



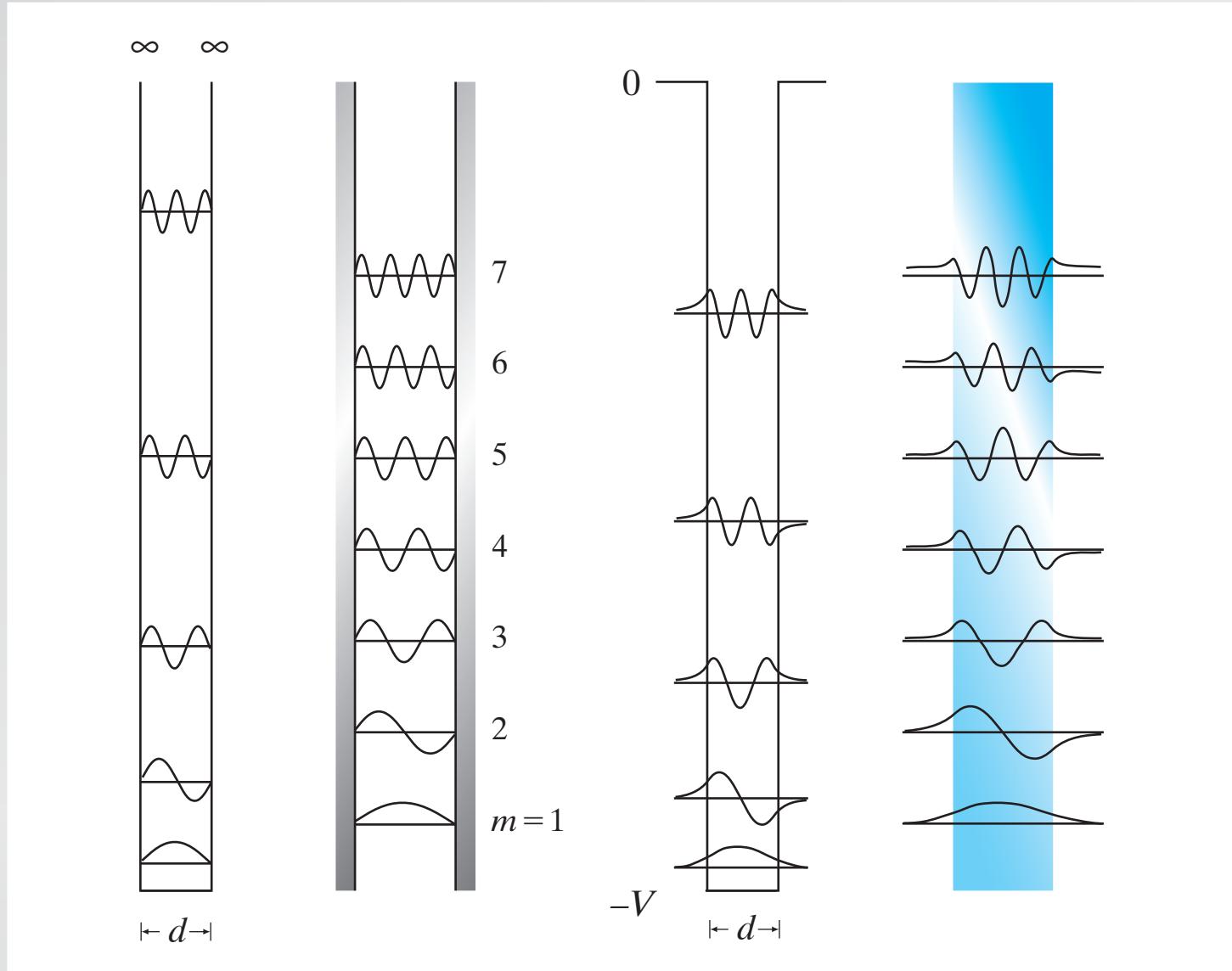
Waveguiding



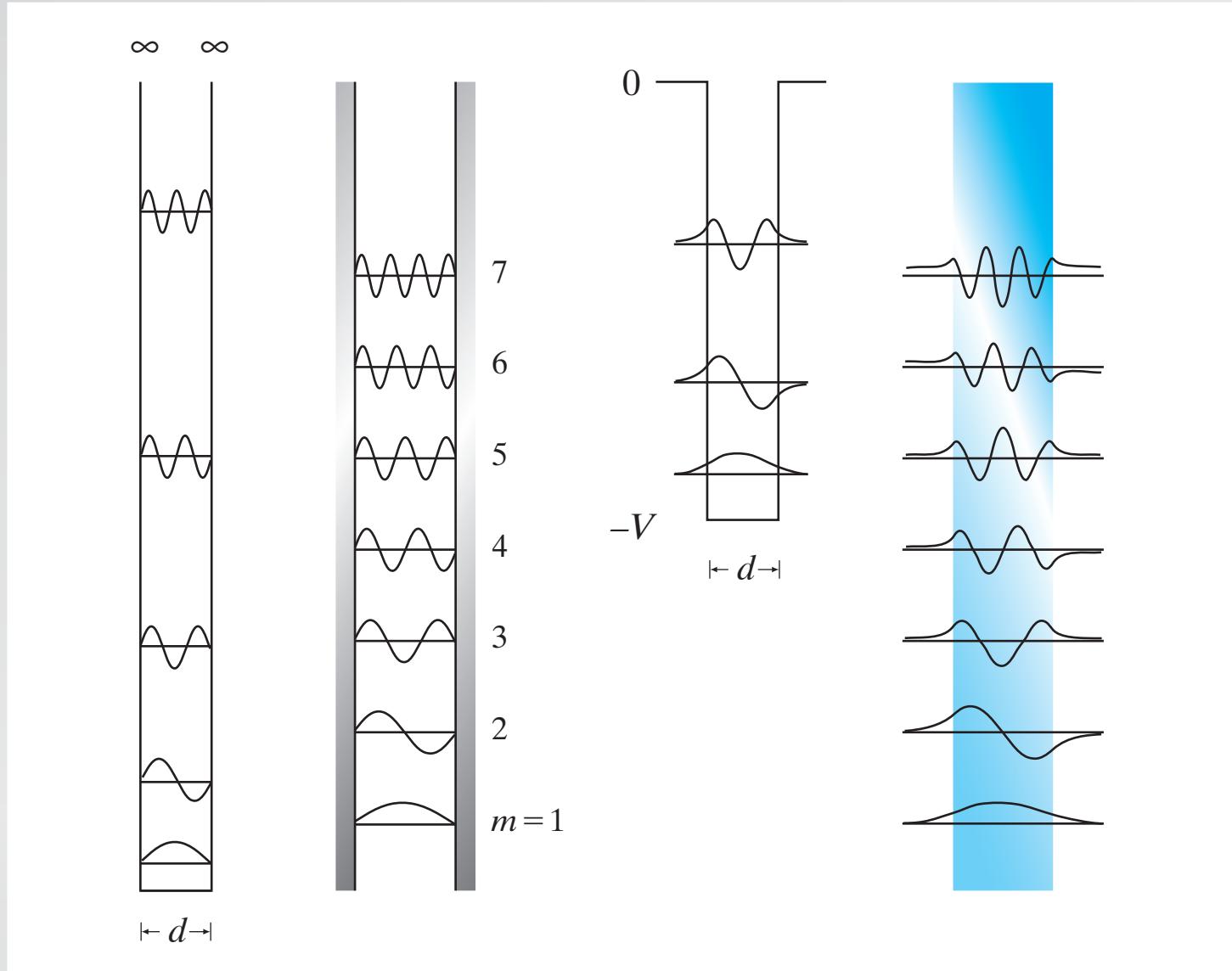
Waveguiding



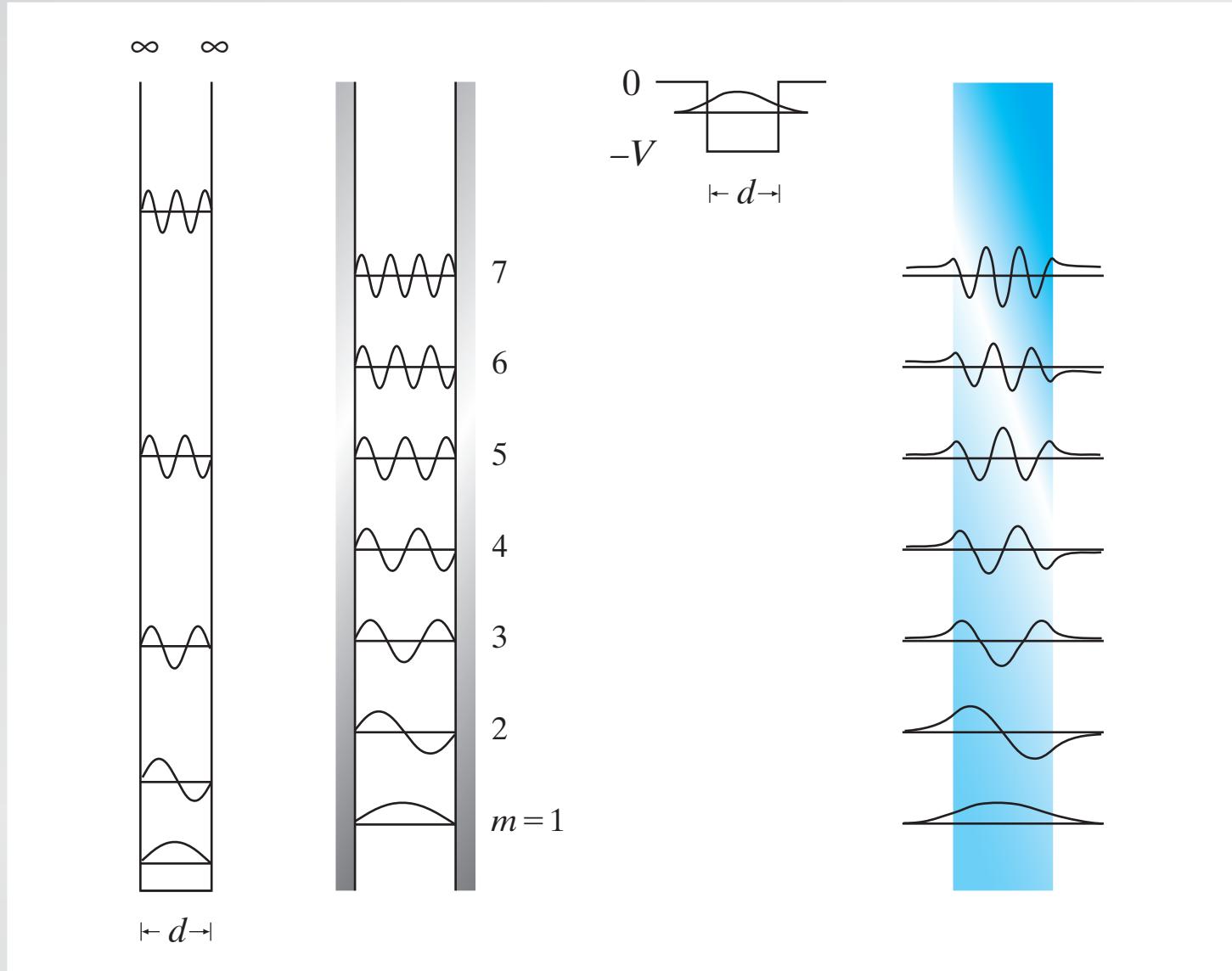
Waveguiding



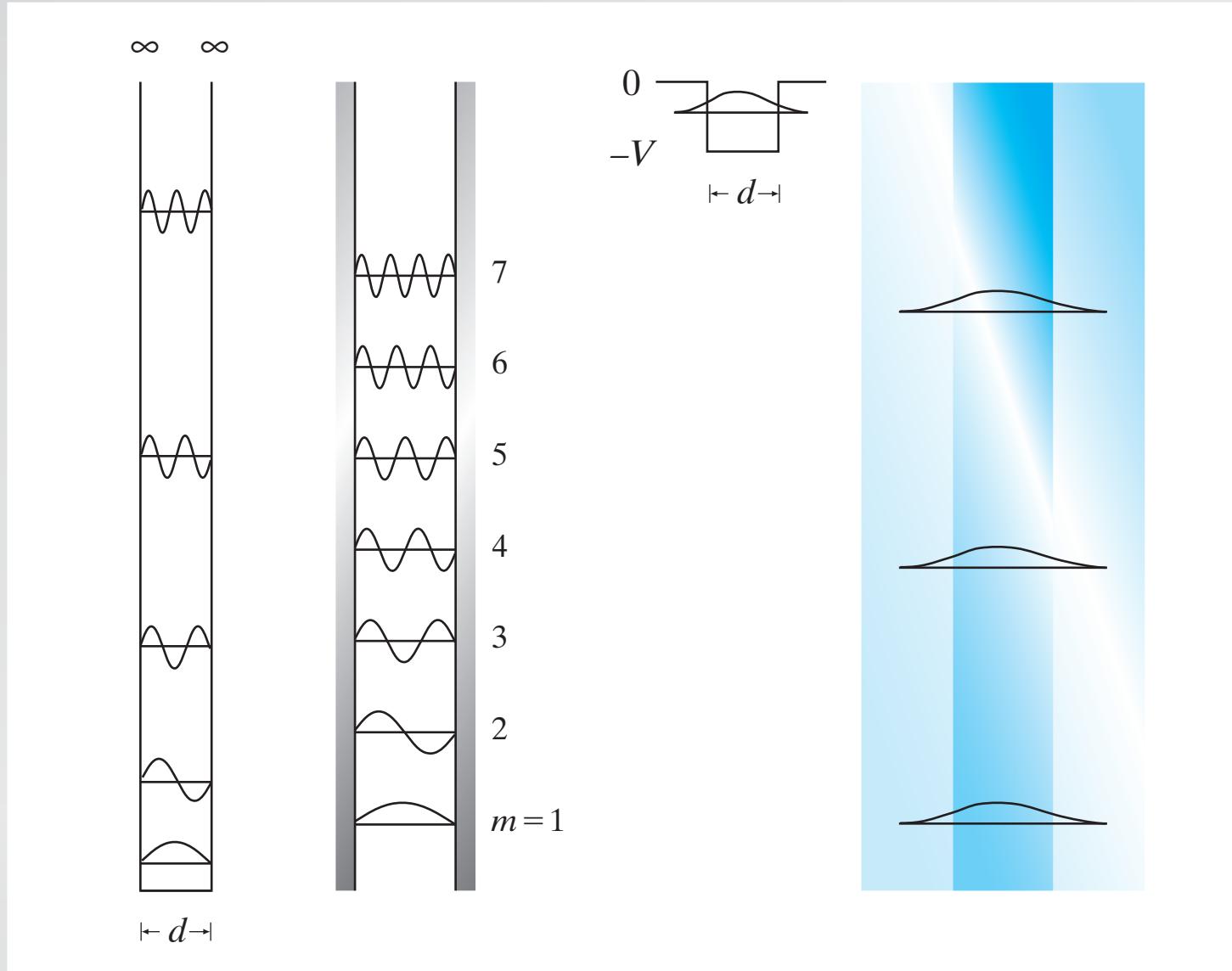
Waveguiding



Waveguiding



Waveguiding



Waveguiding

single mode condition for 600-nm light:

$$M \doteq 2 \frac{d}{\lambda} (n_1^2 - n_2^2)^{1/2}$$

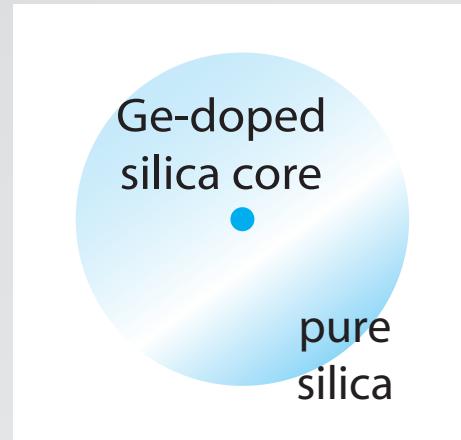
without cladding: $d < 268 \text{ nm}$

Add cladding with 0.4% index difference:

$$d < 5 \mu\text{m}$$

Waveguiding

commercial single-mode fiber (Corning Titan®)



core

cladding

index

$n_1 = 1.468$

$n_2 = 1.462$

diameter:

$8.3 \mu\text{m}$

$125.0 \pm 1.0 \mu\text{m}$

operating wavelength: $\lambda = 1310 \text{ nm}/1550 \text{ nm}$

Waveguiding

drawbacks of clad fibers:

- weak confinement
- no tight bending
- coupling requires splicing

Outline

- waveguiding
- silica nanowires
- manipulating light at the nanoscale
- nanoscale nonlinear optics

Silica nanowires

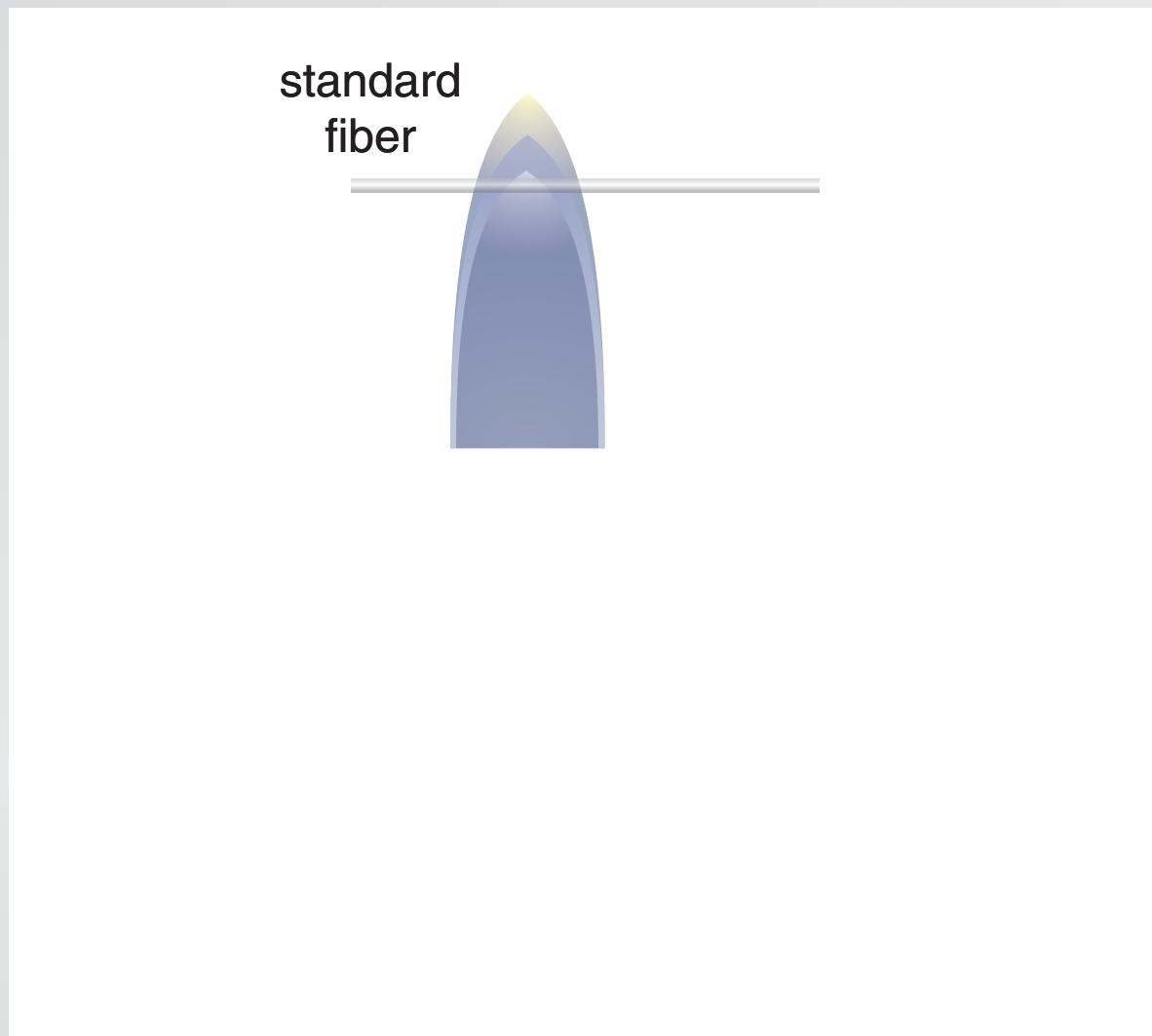
two-step drawing process

standard
fiber



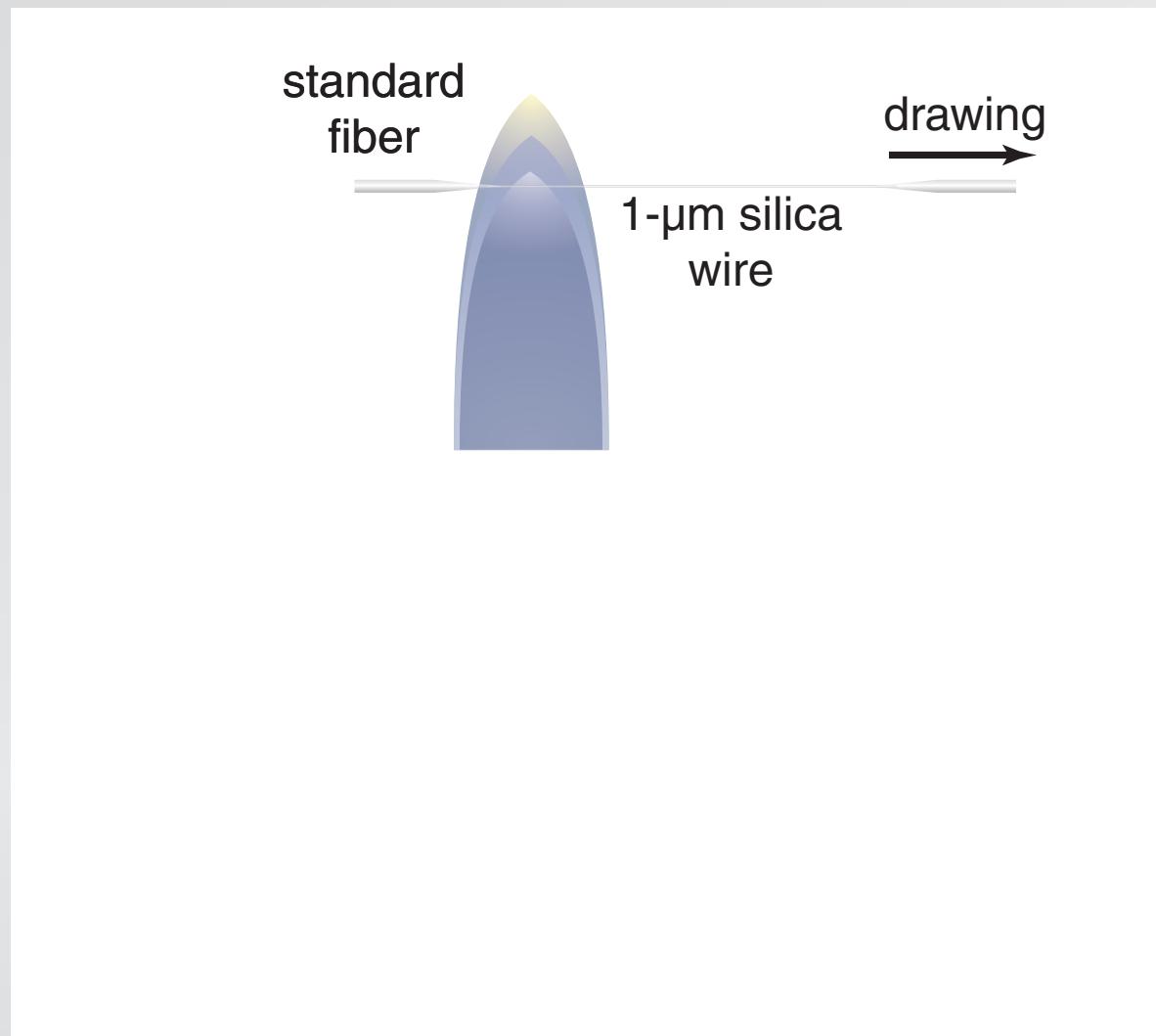
Silica nanowires

two-step drawing process



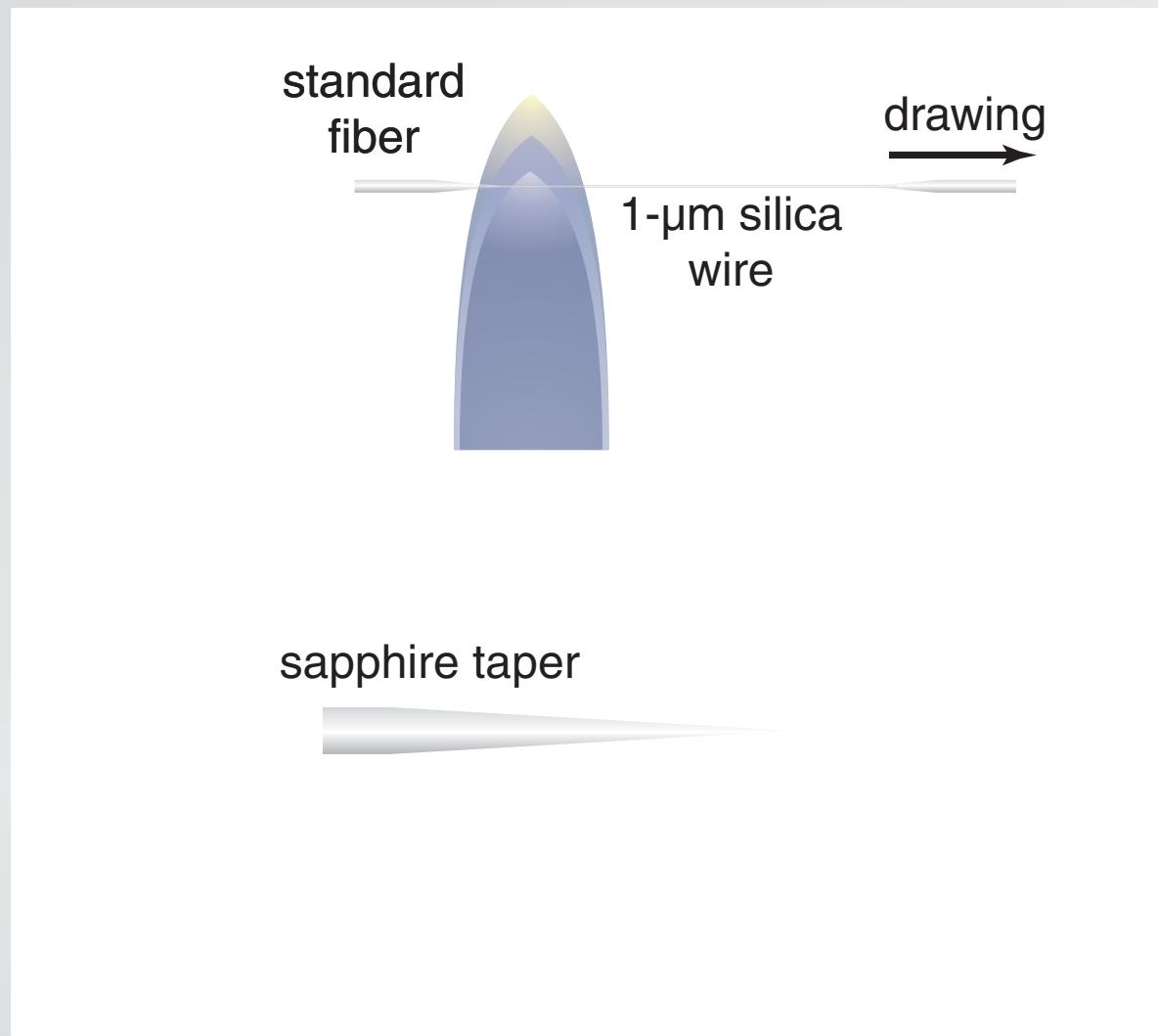
Silica nanowires

two-step drawing process



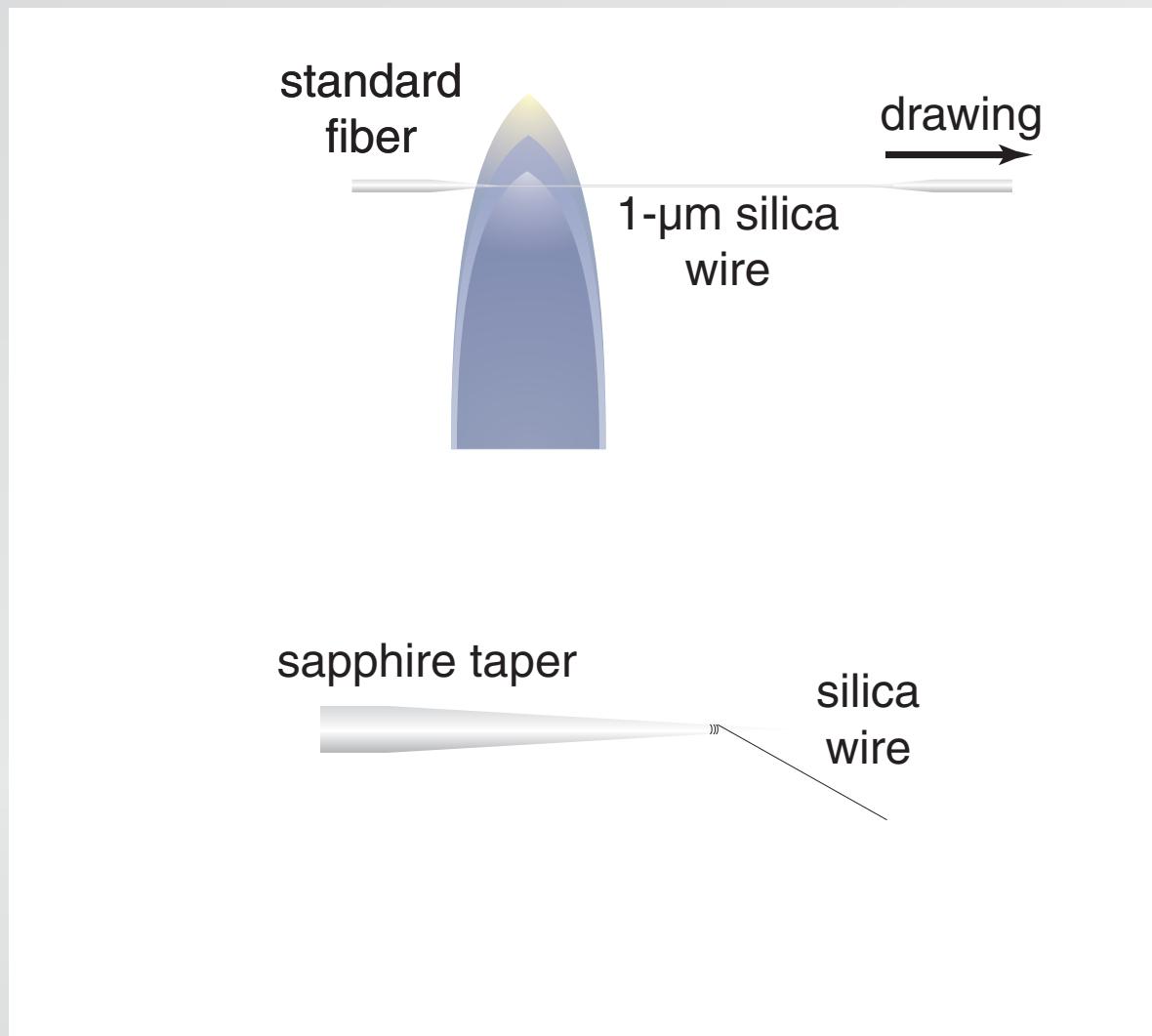
Silica nanowires

two-step drawing process



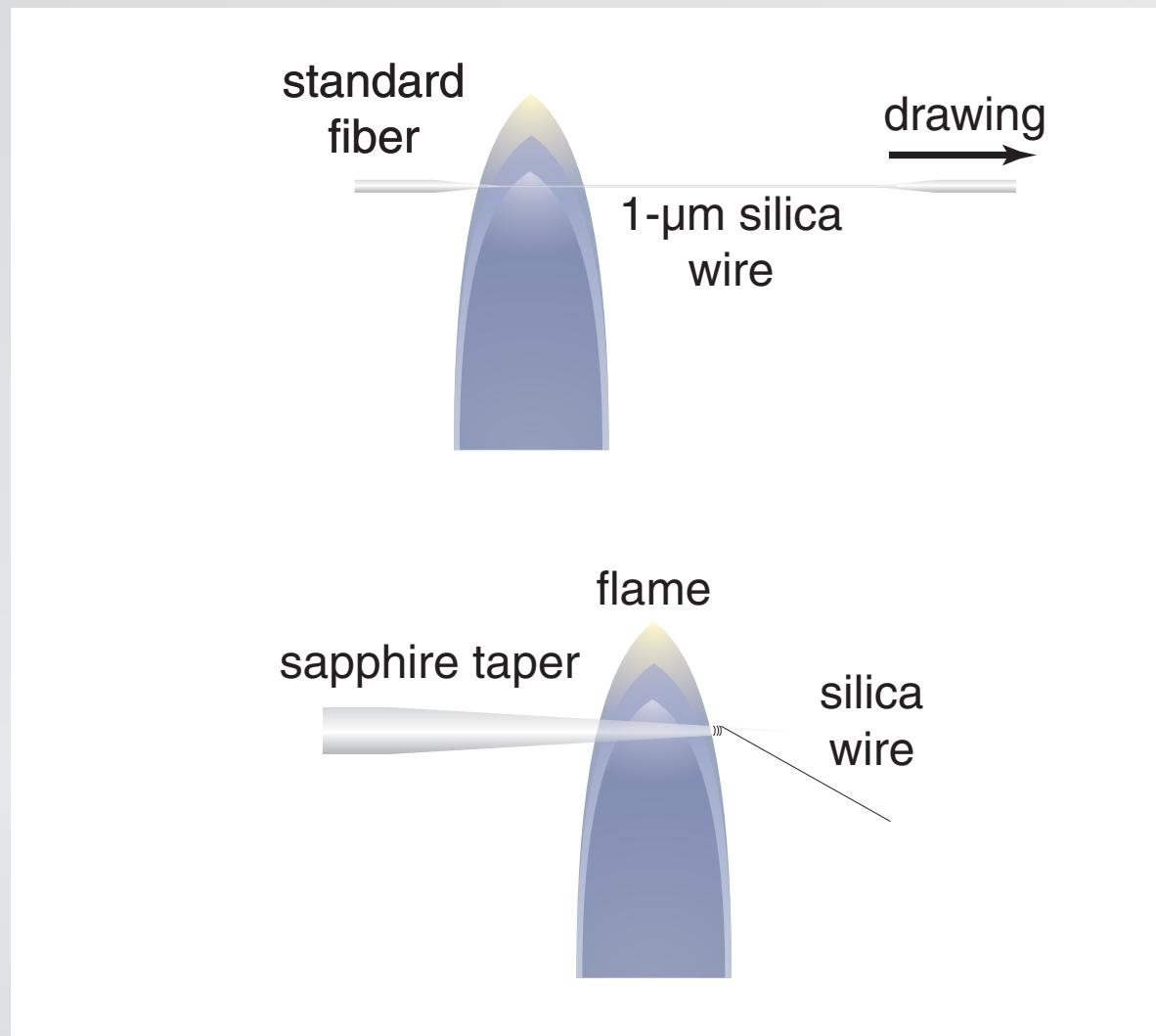
Silica nanowires

two-step drawing process



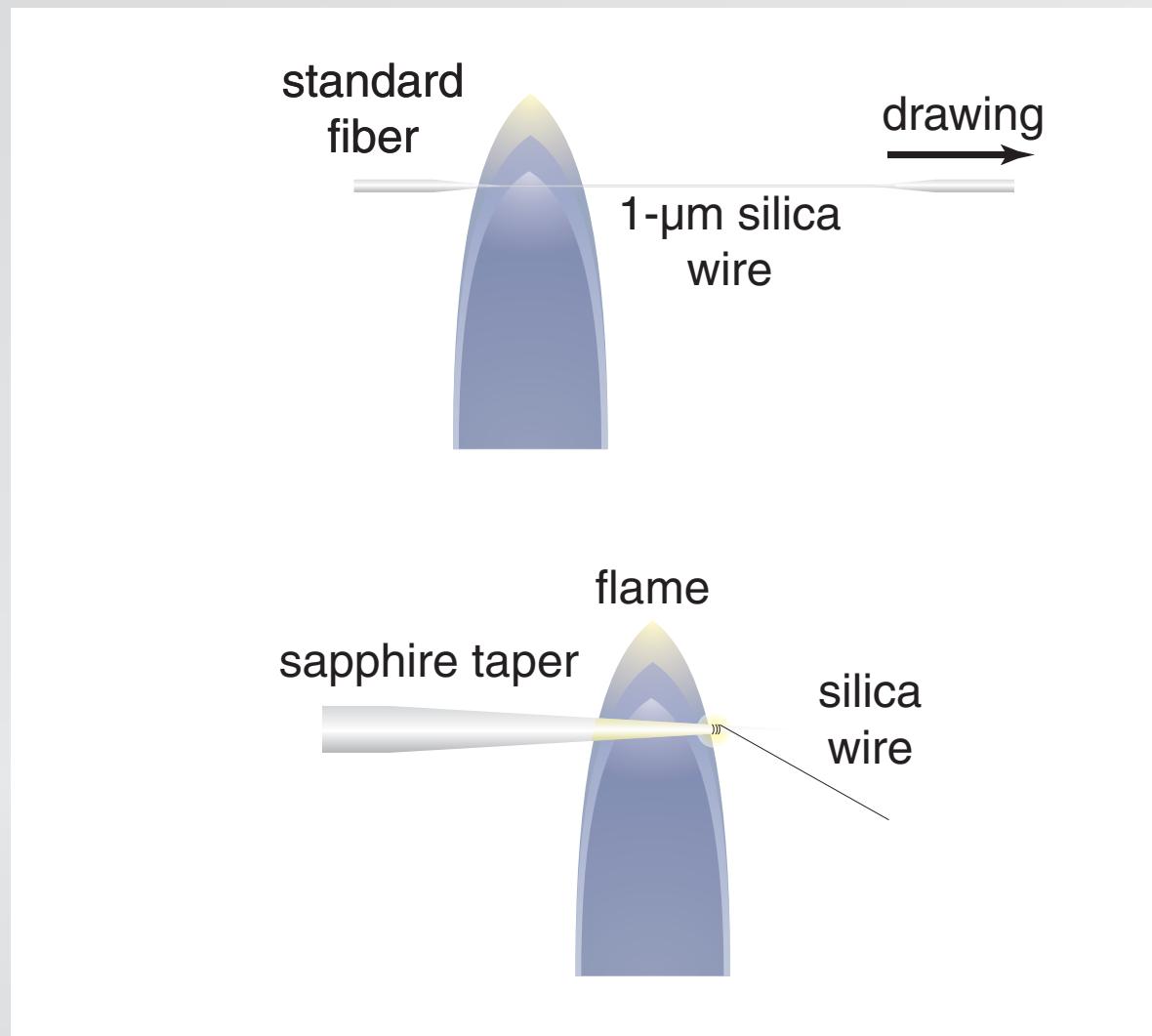
Silica nanowires

two-step drawing process



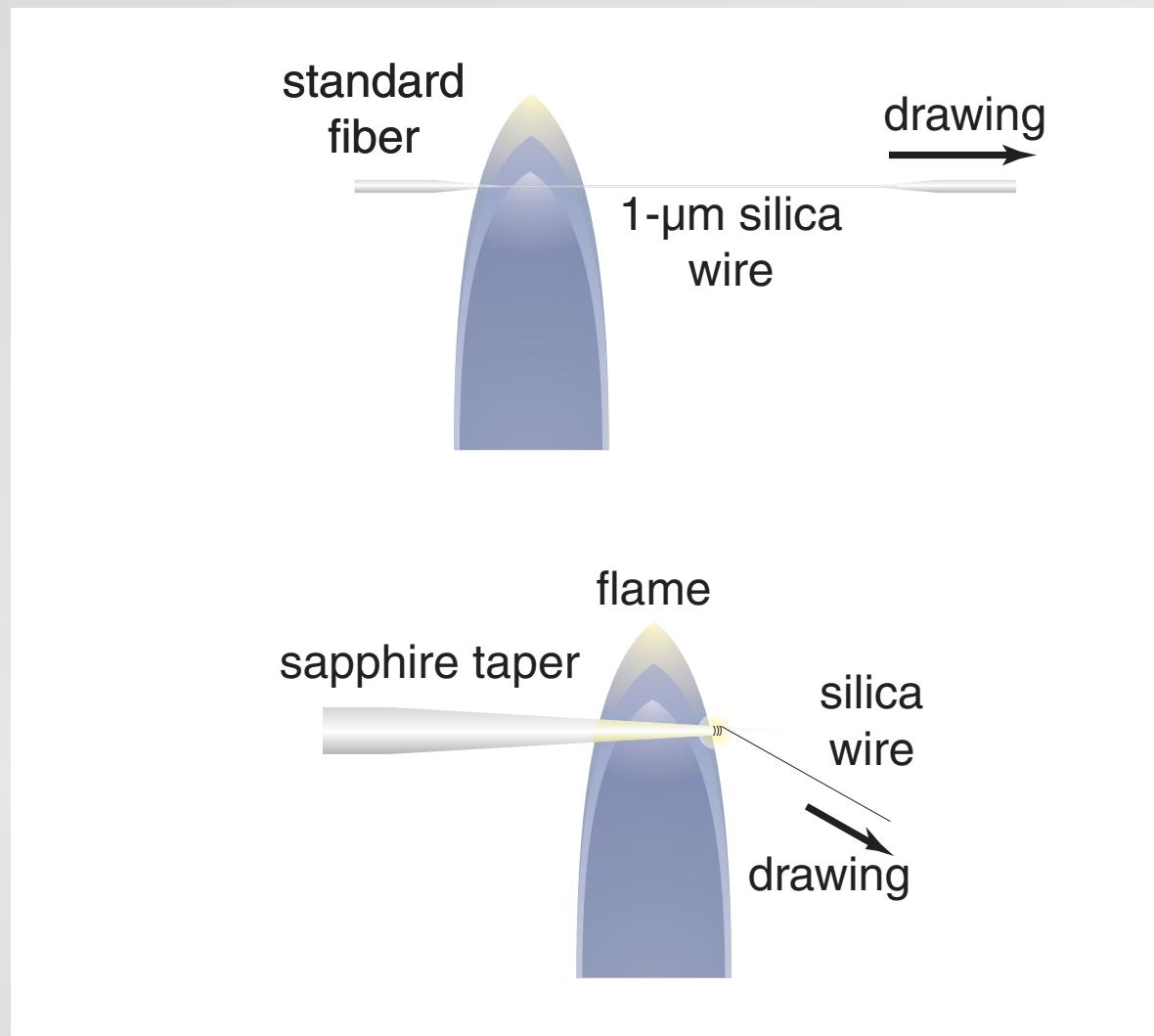
Silica nanowires

two-step drawing process

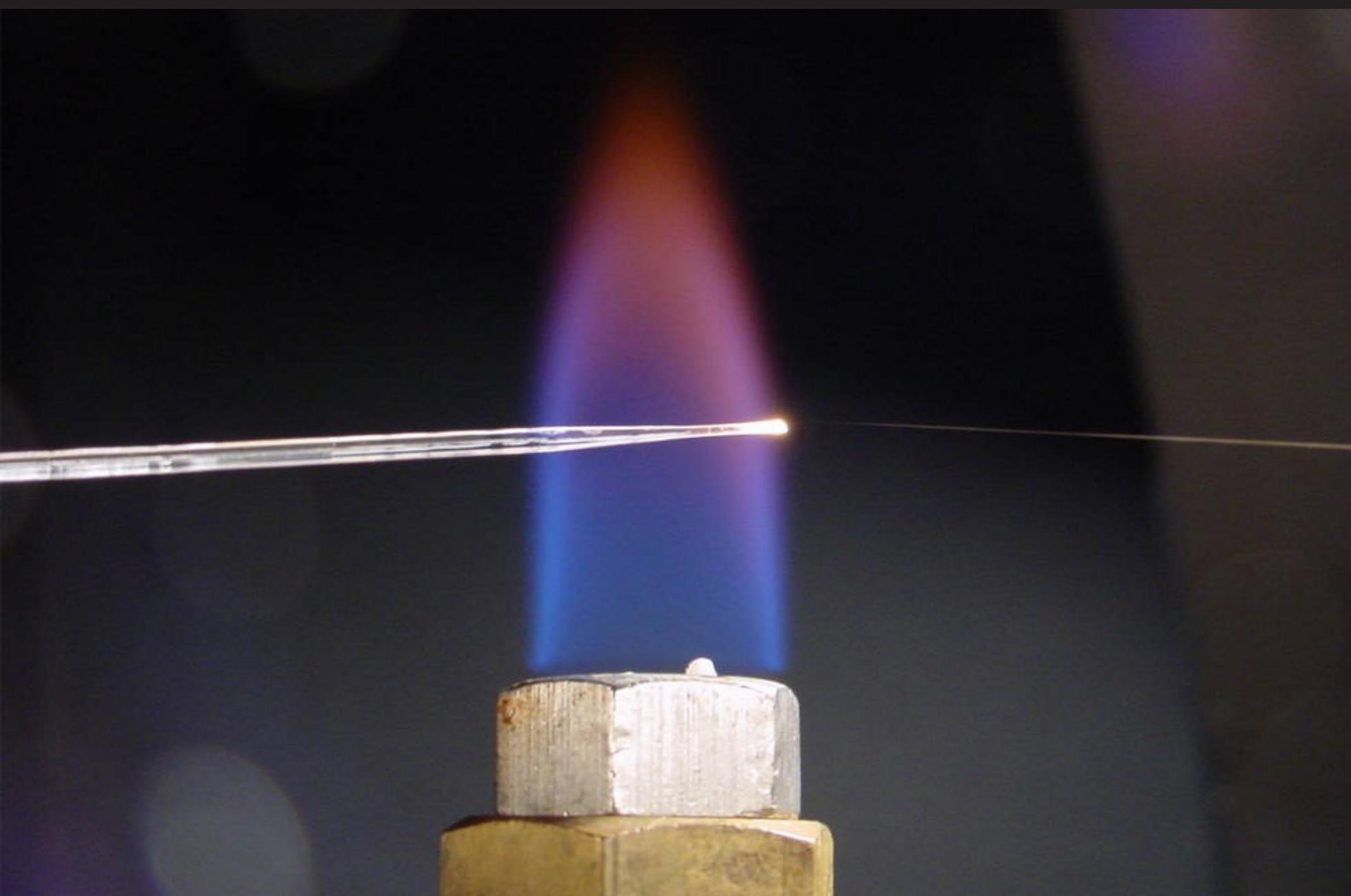


Silica nanowires

two-step drawing process



Silica nanowires



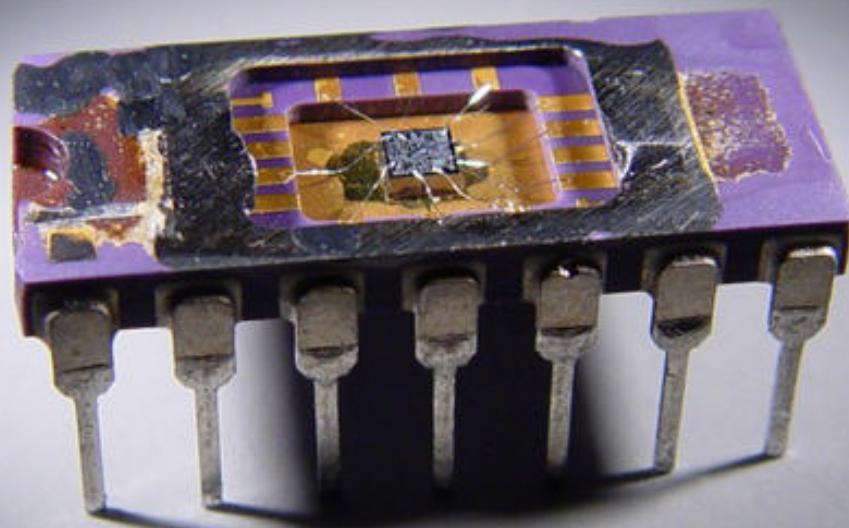
Silica nanowires

1 μm

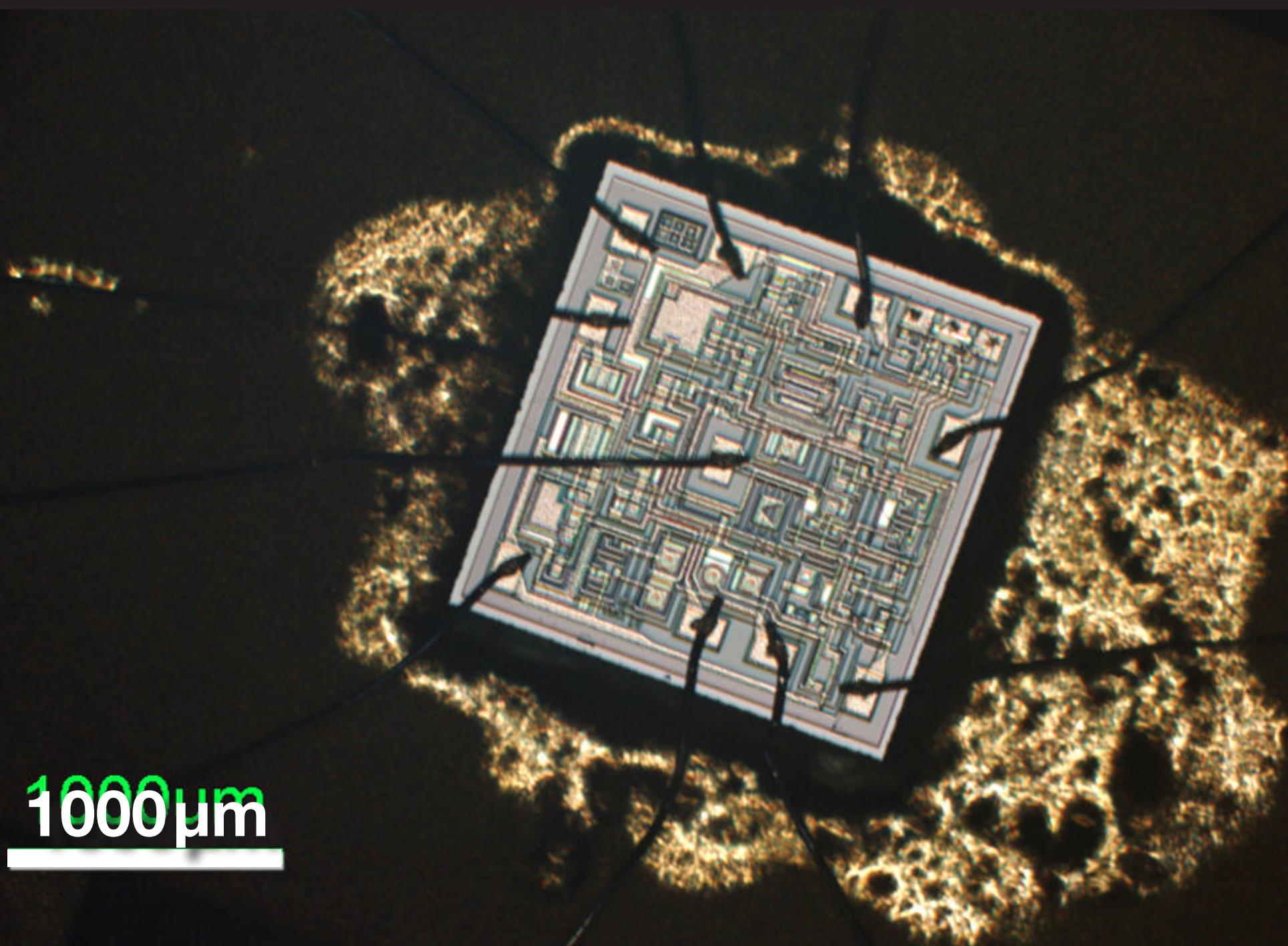


Nature, 426, 816 (2003)

Silica nanowires



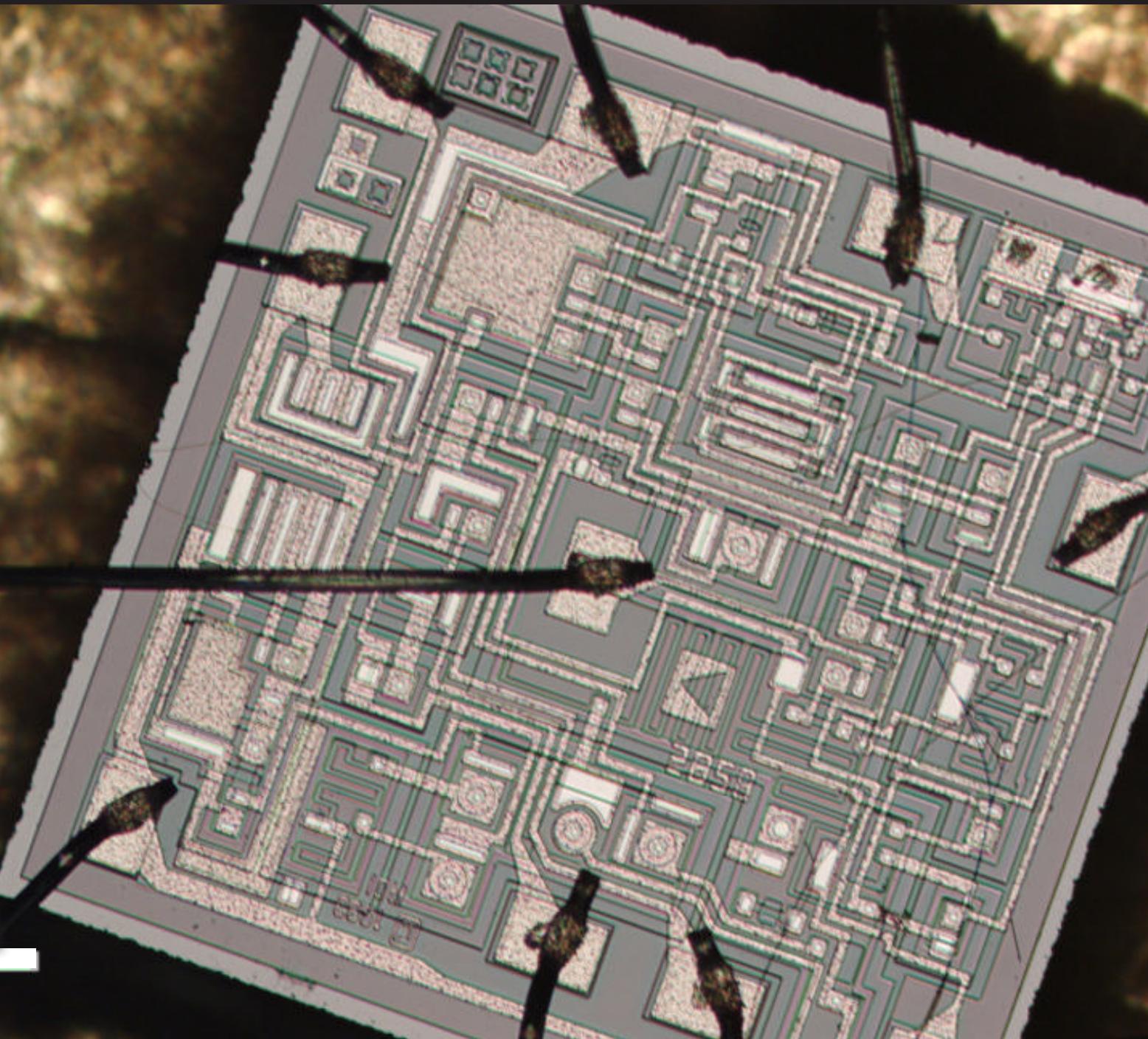
Silica nanowires



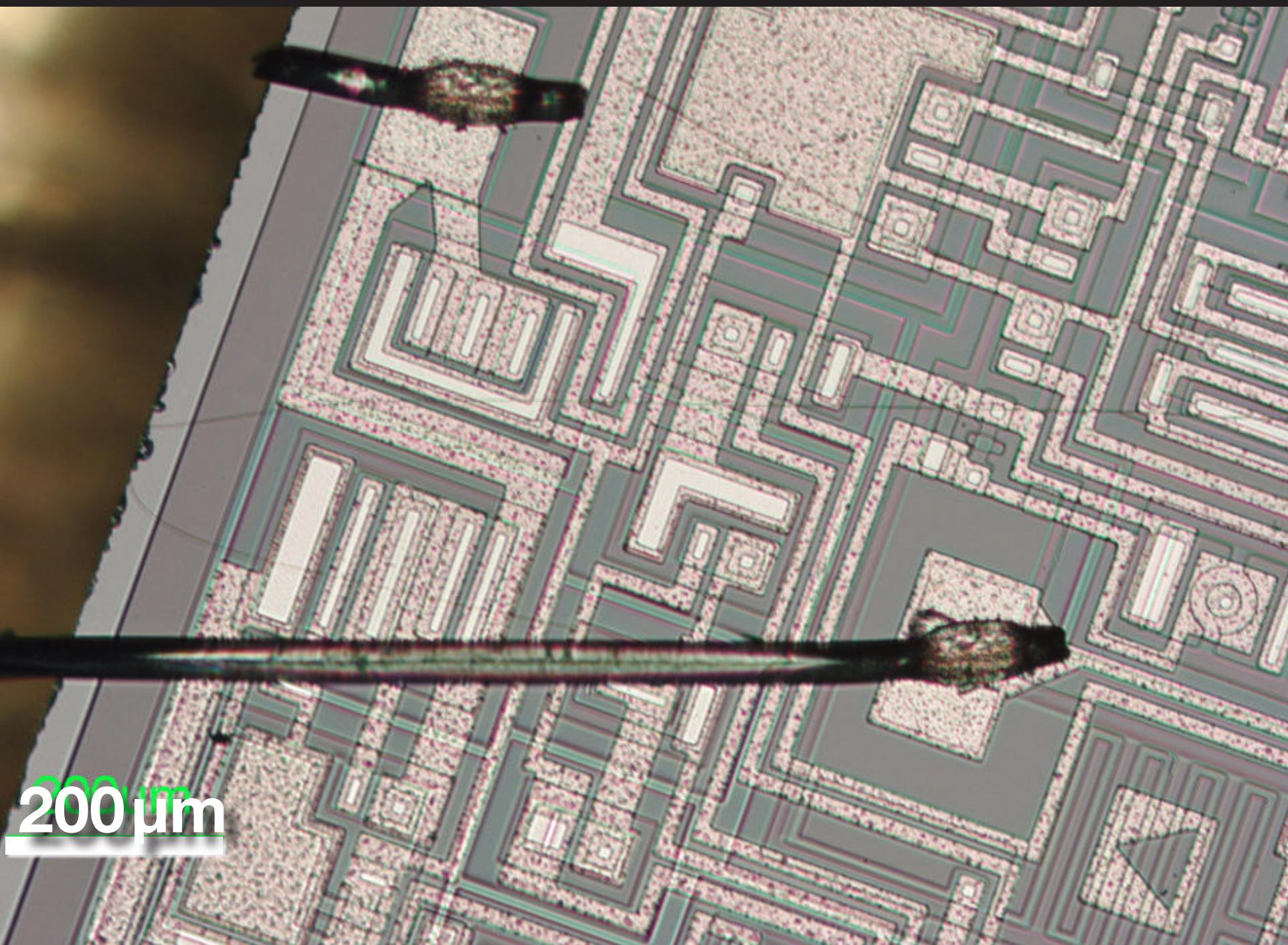
1000 μm

Silica nanowires

500 μm

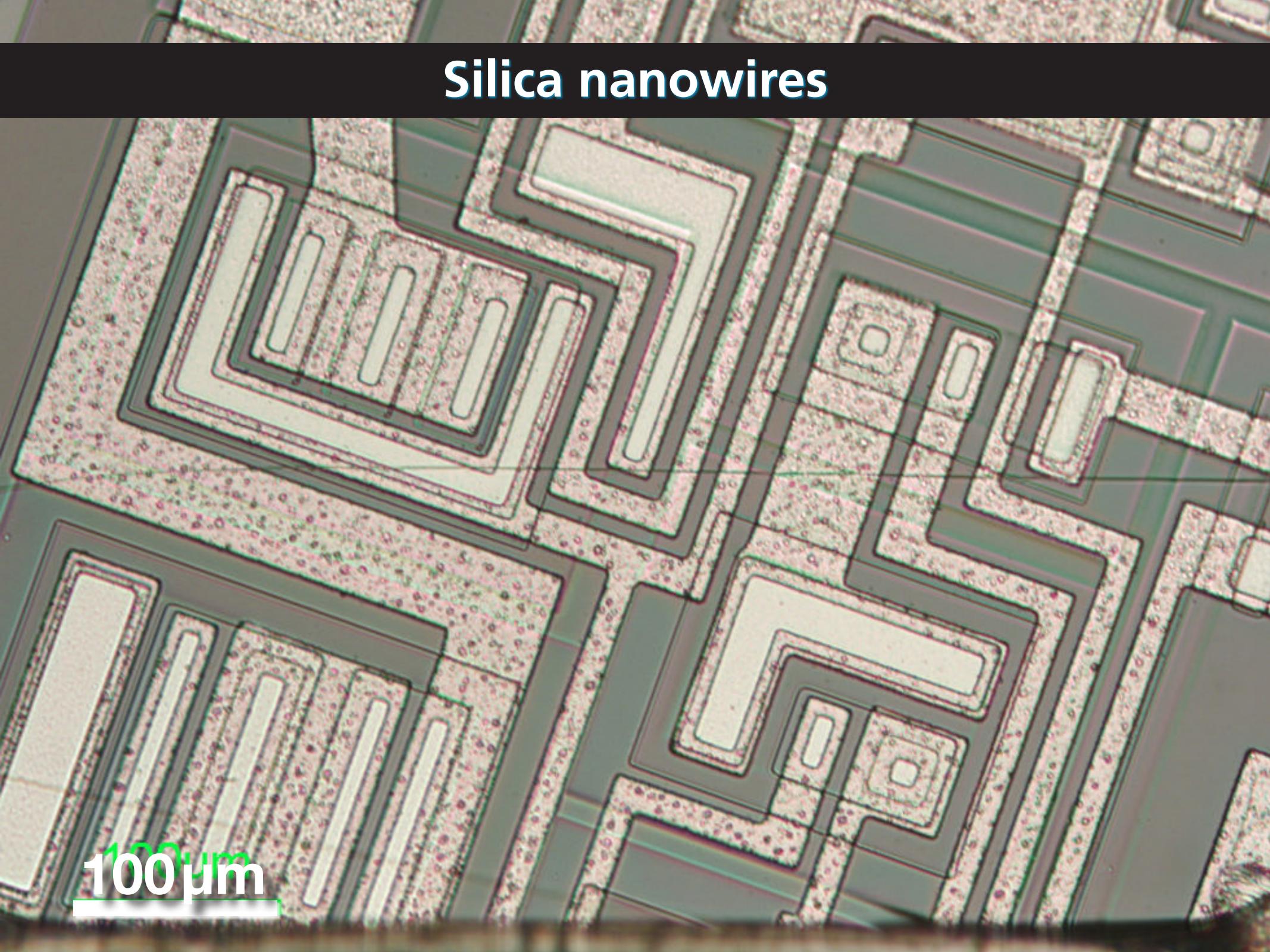


Silica nanowires



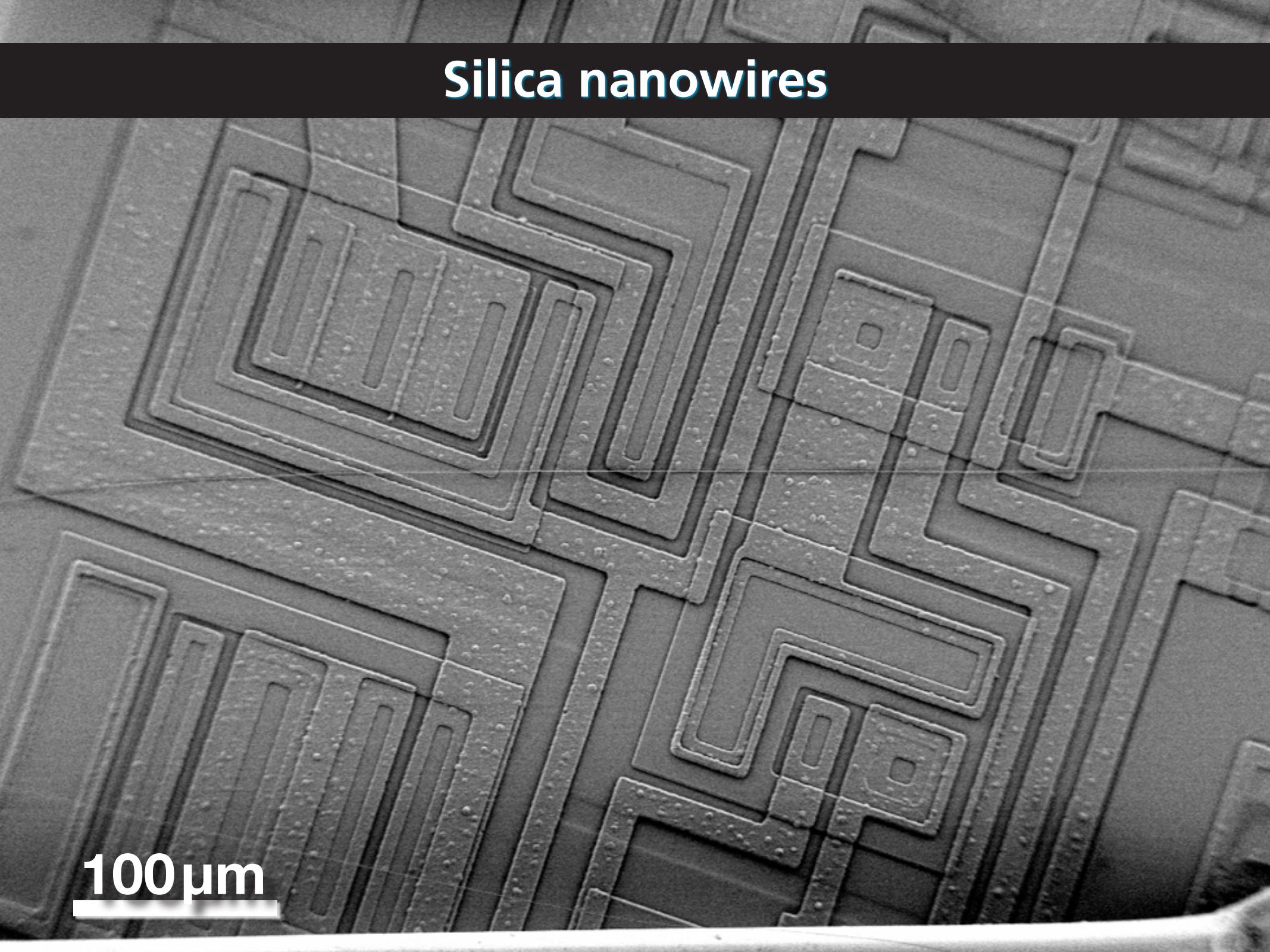
200 μm

Silica nanowires



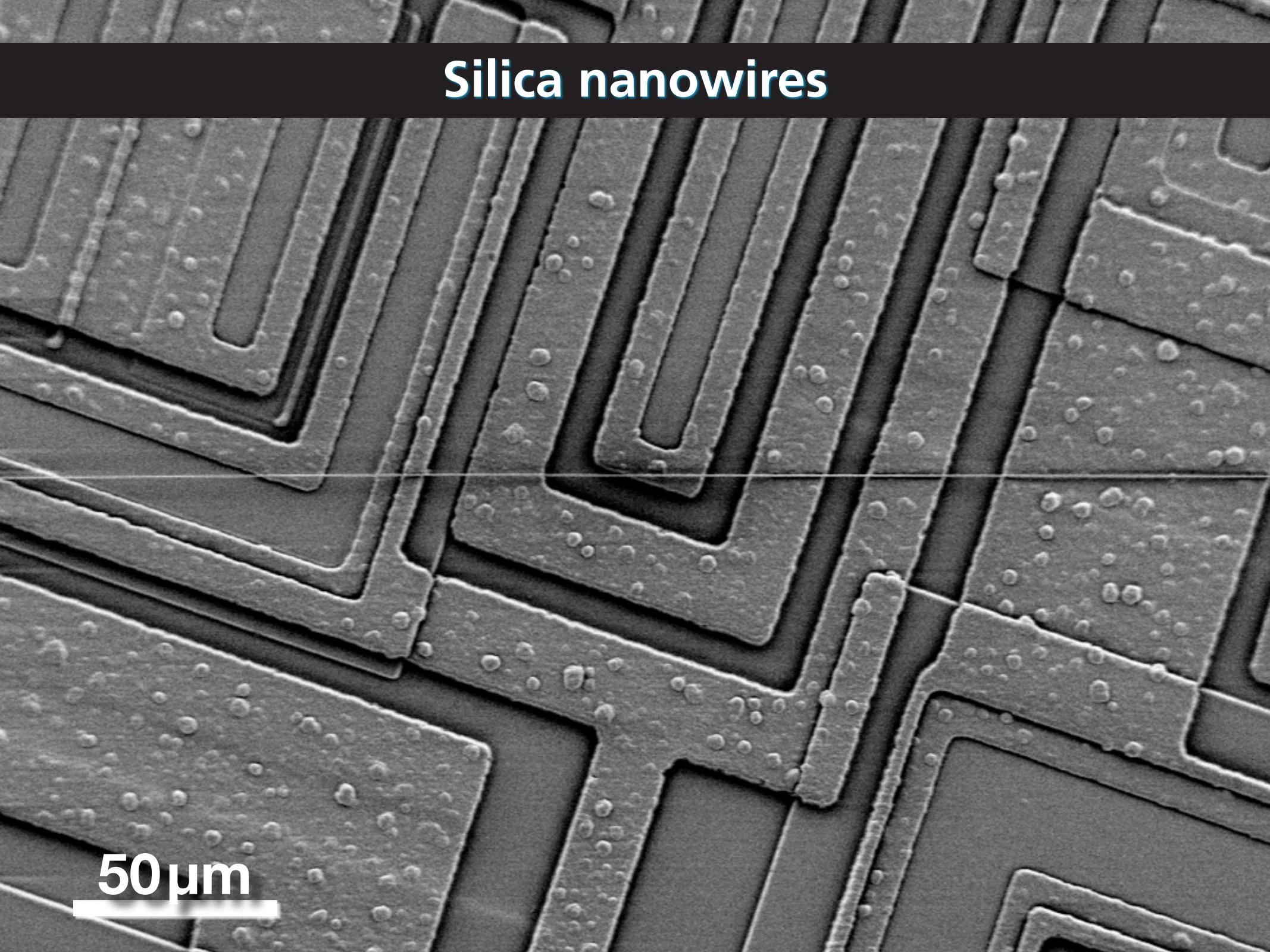
100 μm

Silica nanowires



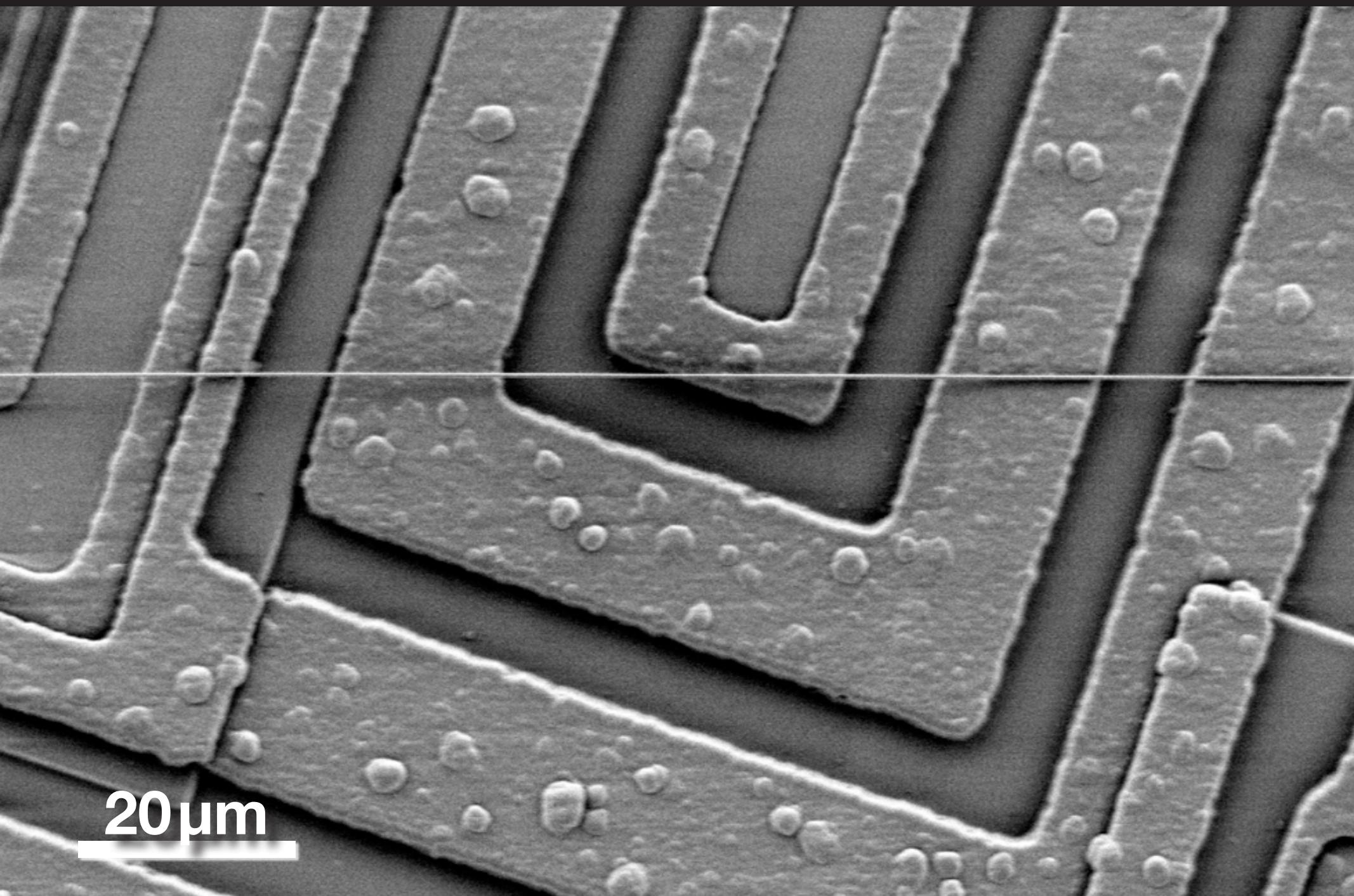
100 μm

Silica nanowires



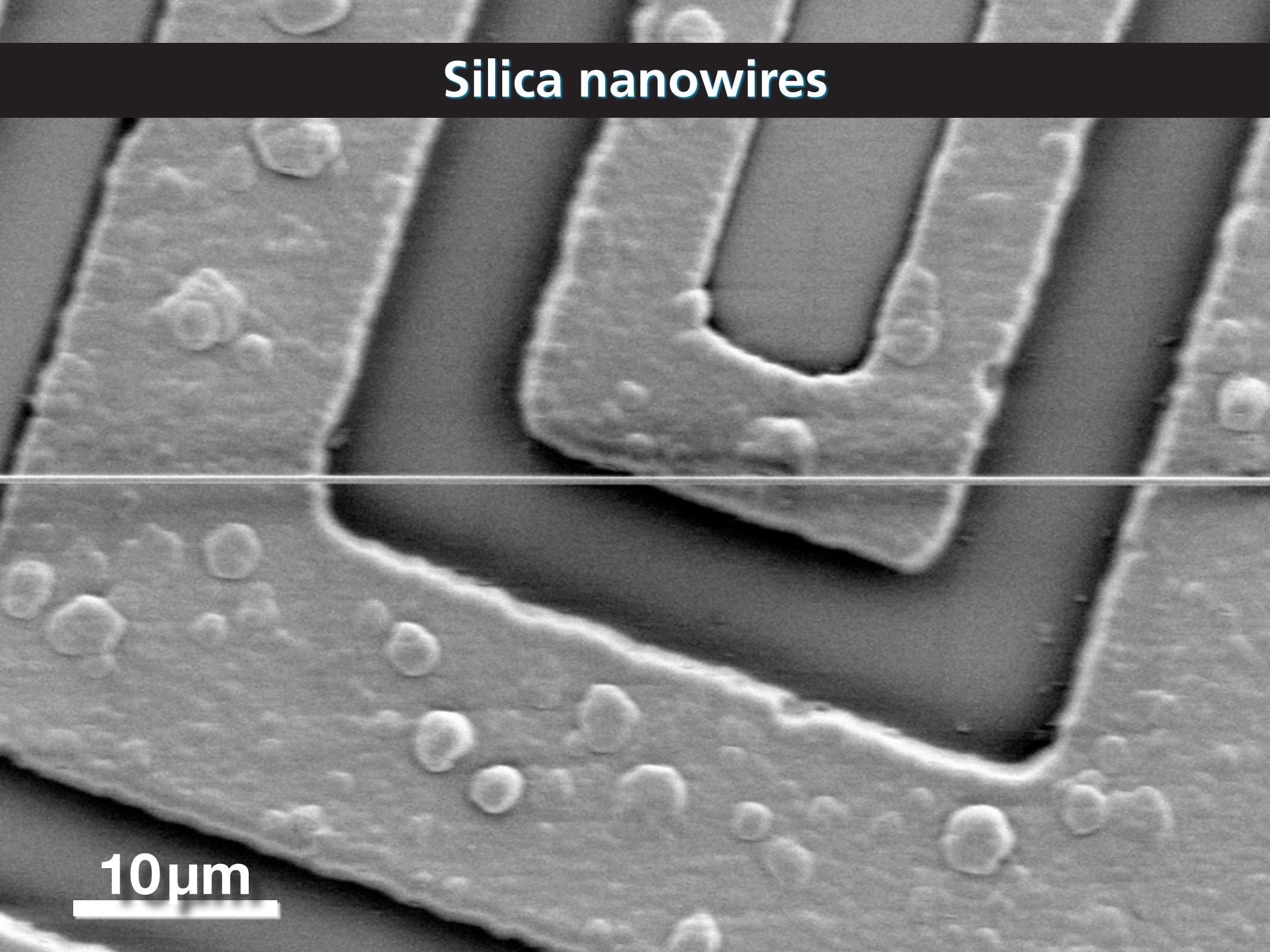
50 μm

Silica nanowires



20 μm

Silica nanowires



10 μ m

Silica nanowires

6 μ m

Silica nanowires

4 μm

Silica nanowires

2 μm

Silica nanowires

312 nm



1 μ m

Silica nanowires

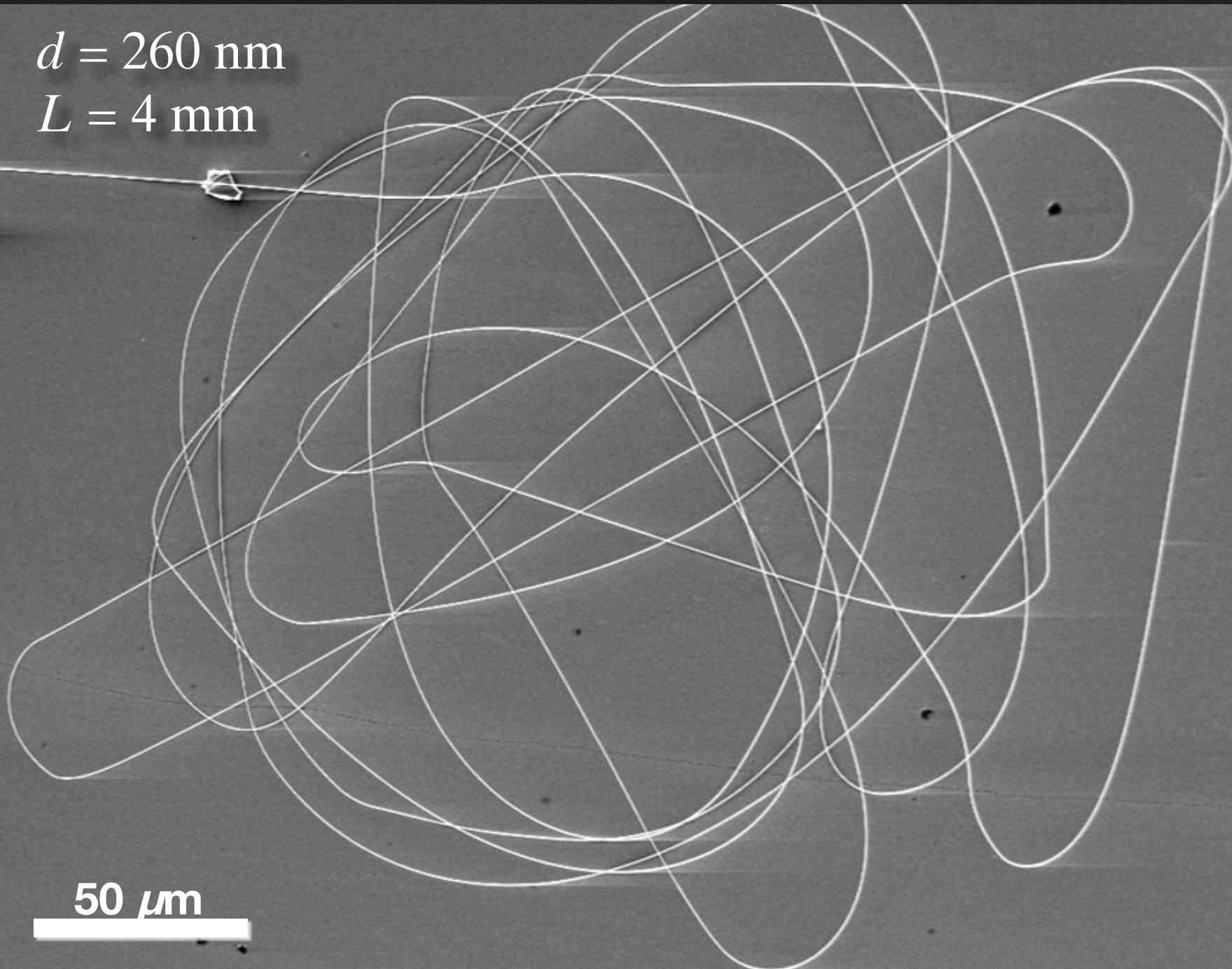
Specifications

diameter D:	down to 20 nm
length L:	up to 90 mm
aspect ratio D/L:	up to 10^6
diameter uniformity $\Delta D/L$:	2×10^{-6}

Silica nanowires

$d = 260 \text{ nm}$

$L = 4 \text{ mm}$



Silica nanowires

240-nm wire

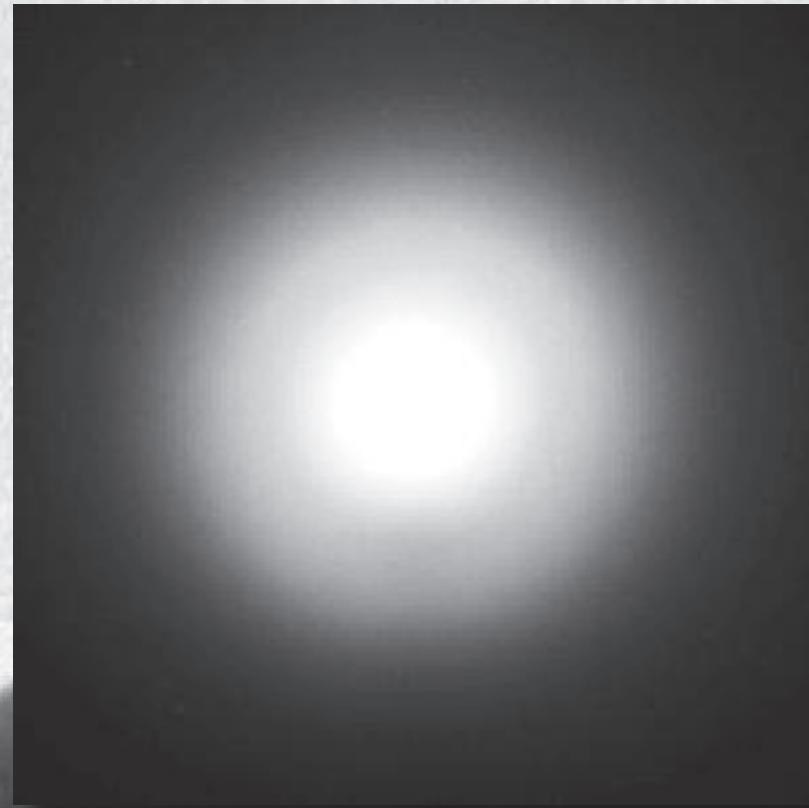
200 nm

Silica nanowires

RMS roughness < 0.5 nm

20 nm

Silica nanowires



20 nm

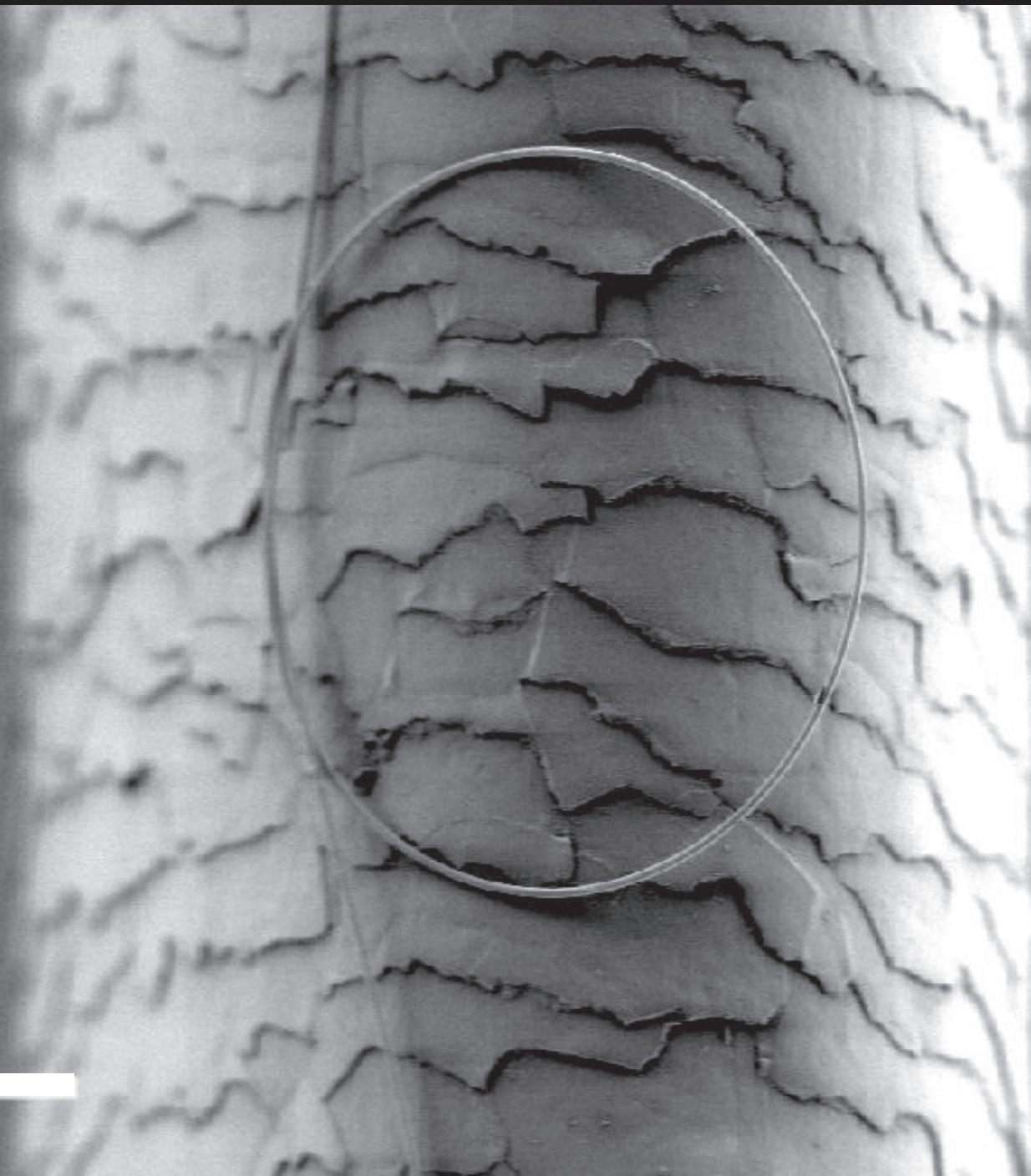
Silica nanowires

2 μm

Silica nanowires

20 μm

Silica nanowires



20 μm

Silica nanowires

Points to keep in mind:

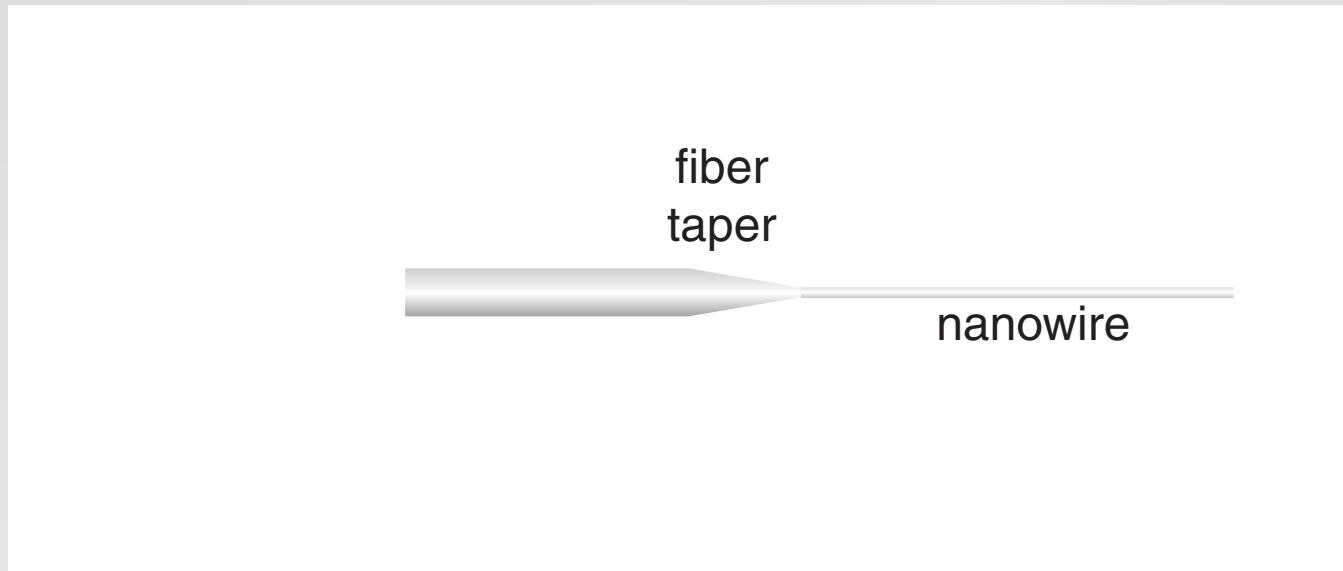
- easy fabrication
- atomic level smoothness
- malleable

Outline

- waveguiding
- silica nanowires
- manipulating light at the nanoscale
- nanoscale nonlinear optics

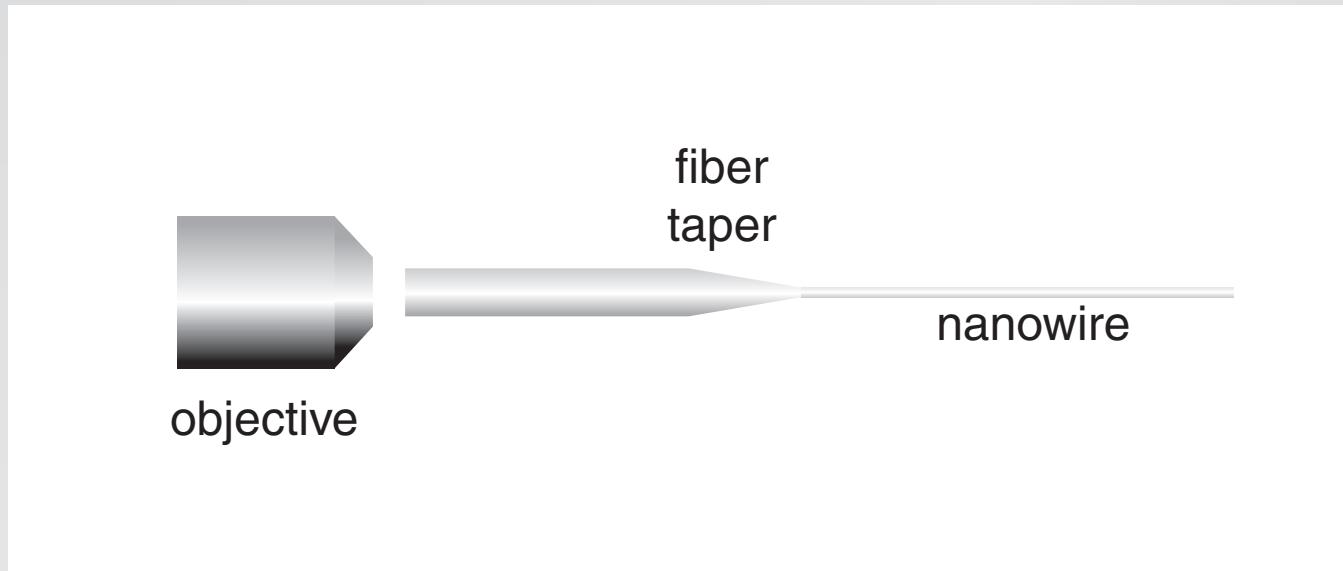
Manipulating light at the nanoscale

coupling light into nanowires



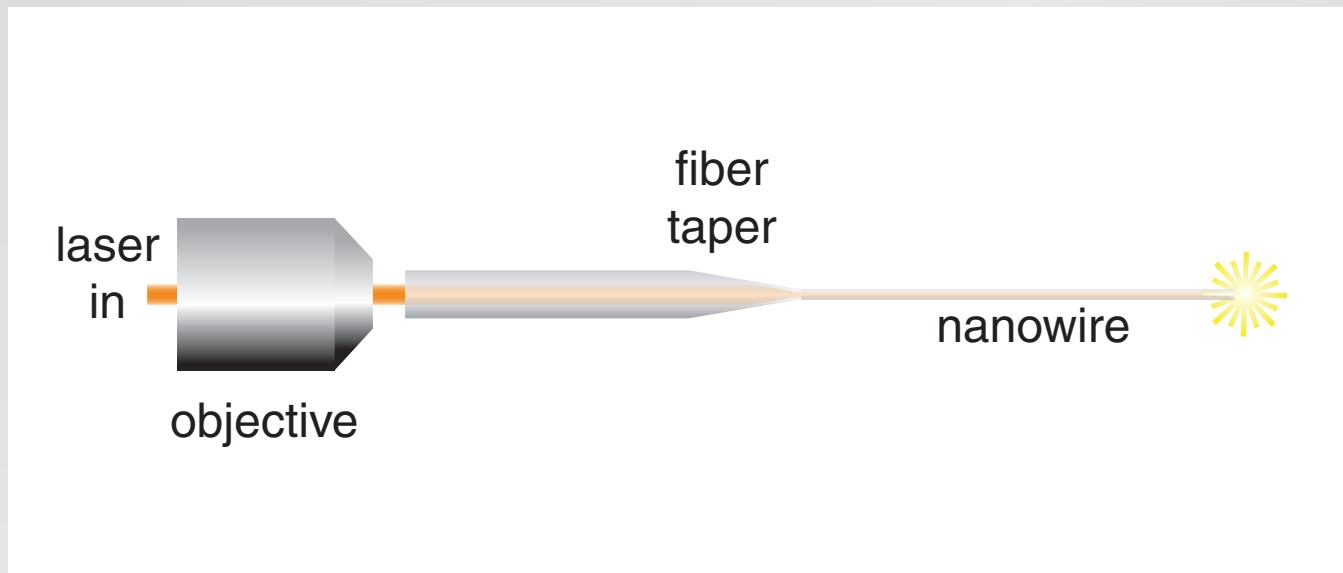
Manipulating light at the nanoscale

coupling light into nanowires



Manipulating light at the nanoscale

coupling light into nanowires



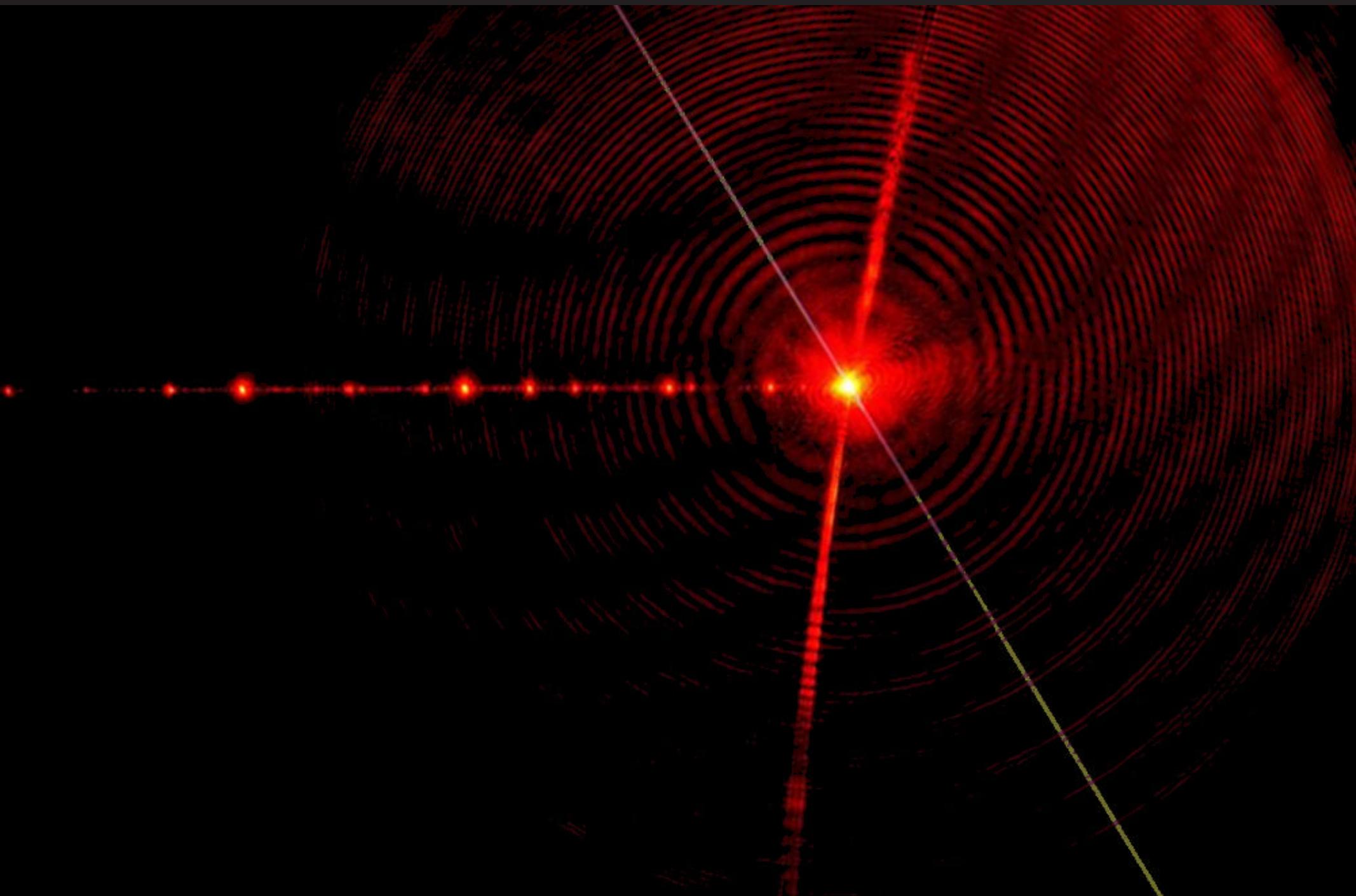
Manipulating light at the nanoscale

280-nm nanowire

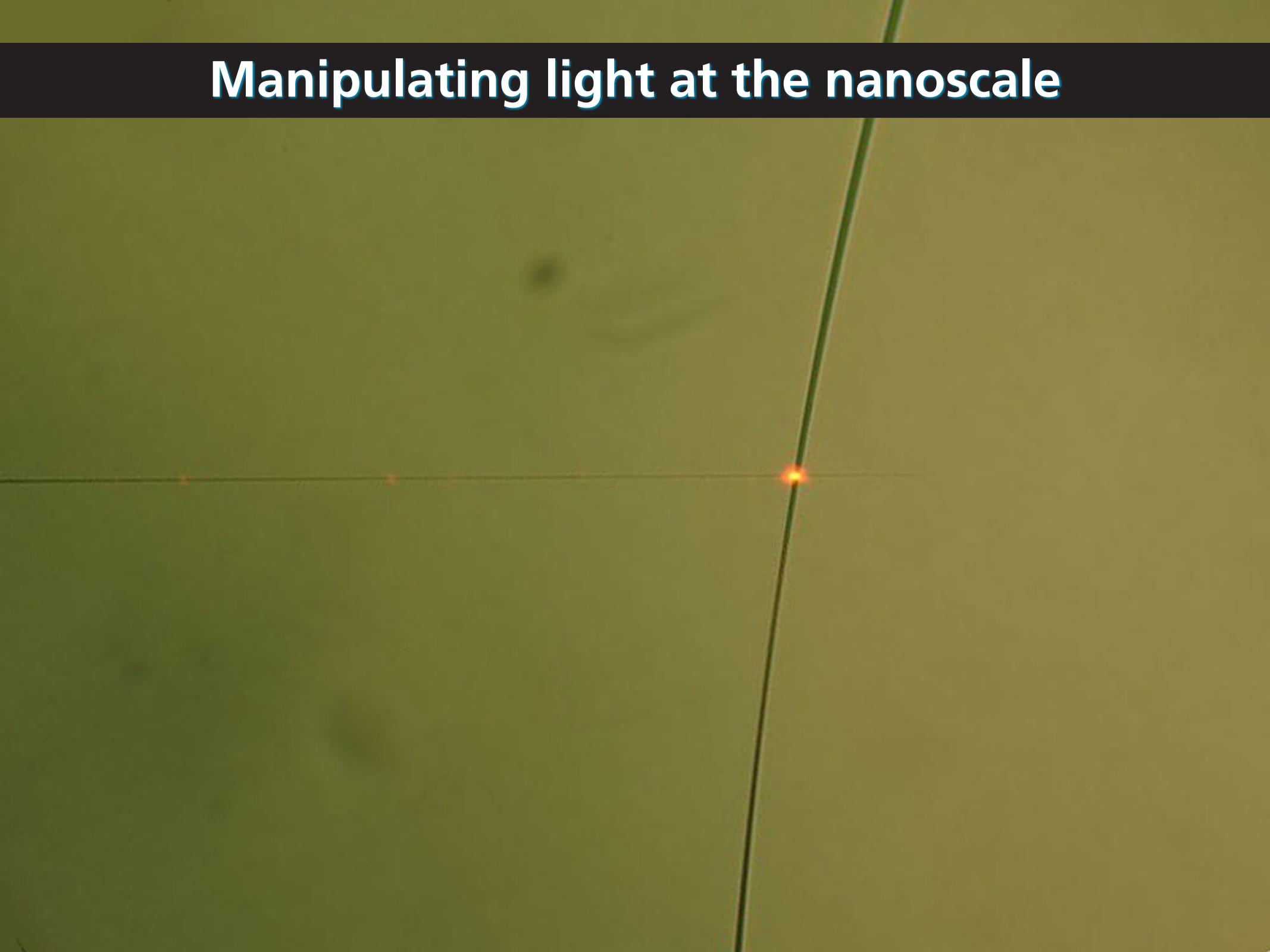
360 nm

450 nm

Manipulating light at the nanoscale

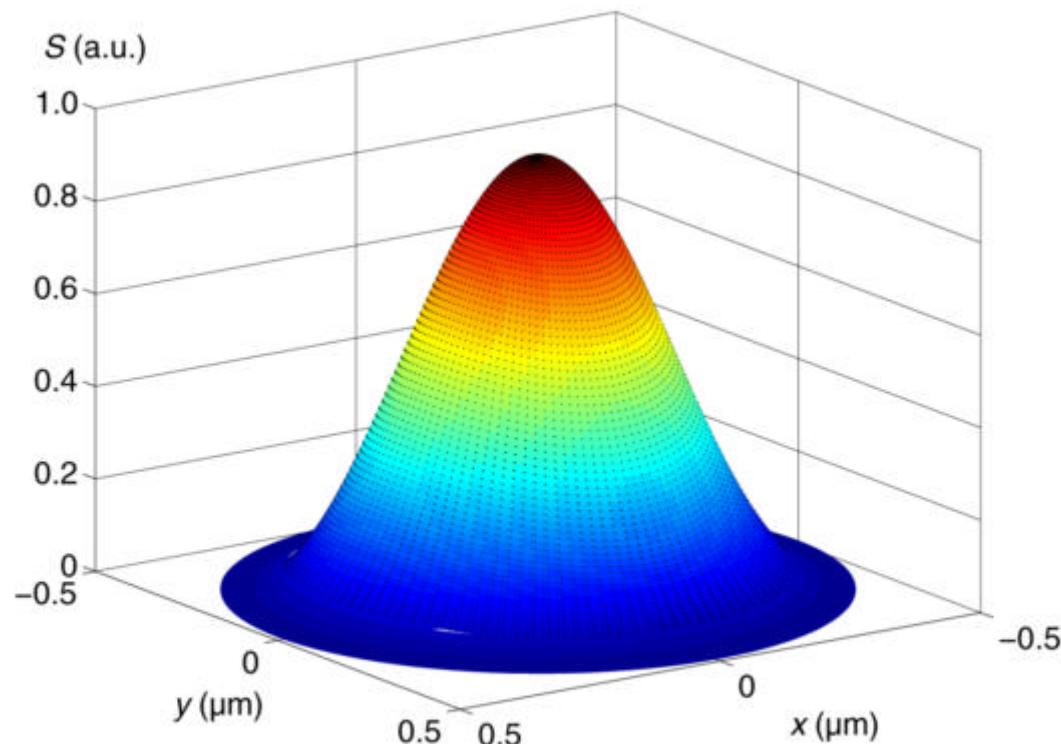


Manipulating light at the nanoscale



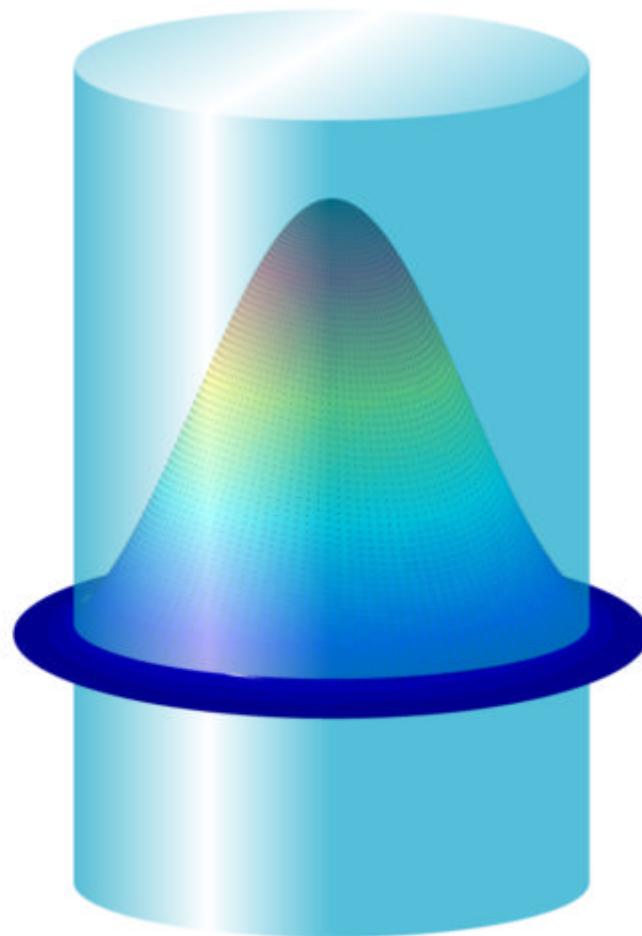
Manipulating light at the nanoscale

Poynting vector profile for 800-nm nanowire



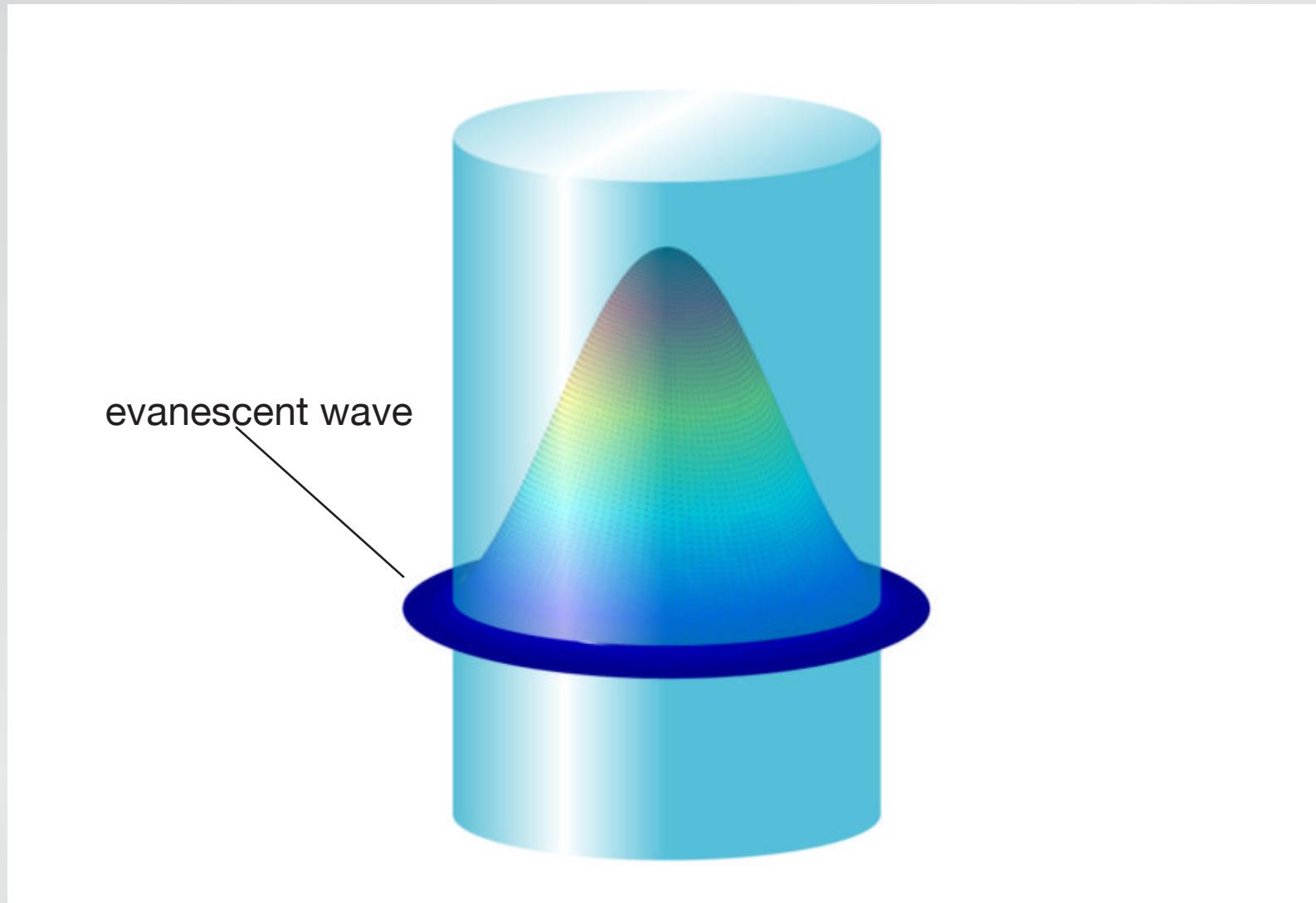
Manipulating light at the nanoscale

Poynting vector profile for 800-nm nanowire



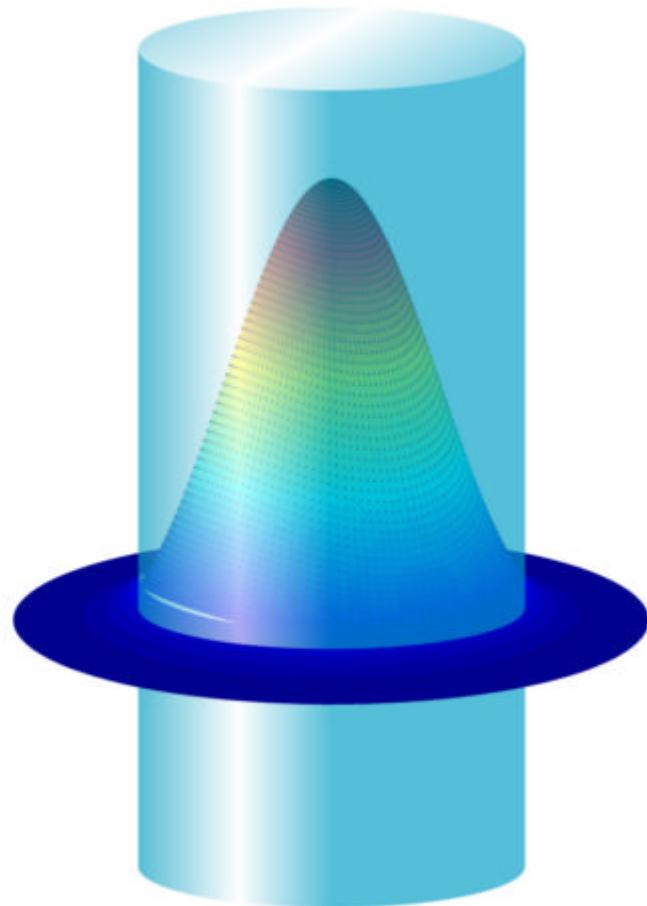
Manipulating light at the nanoscale

Poynting vector profile for 800-nm nanowire



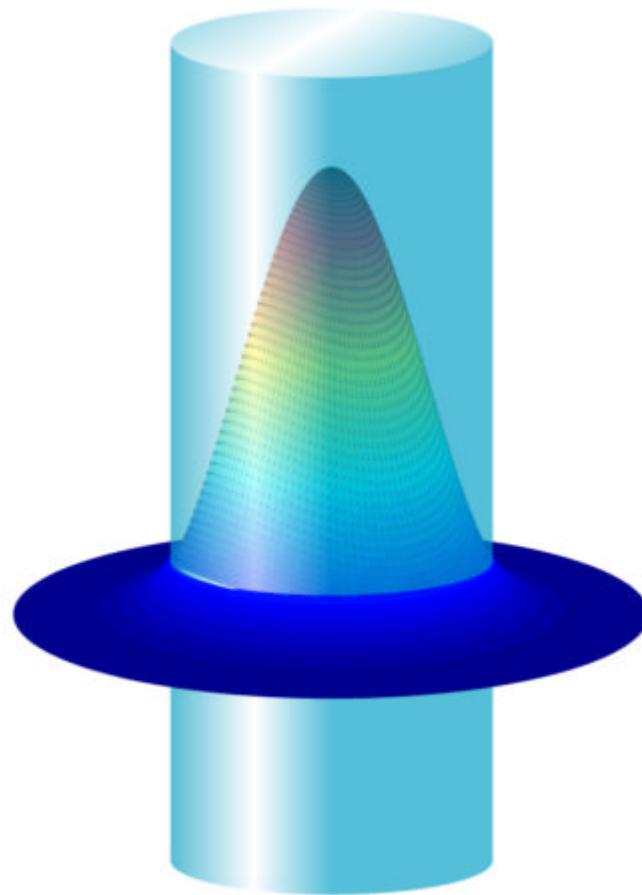
Manipulating light at the nanoscale

Poynting vector profile for 600-nm nanowire



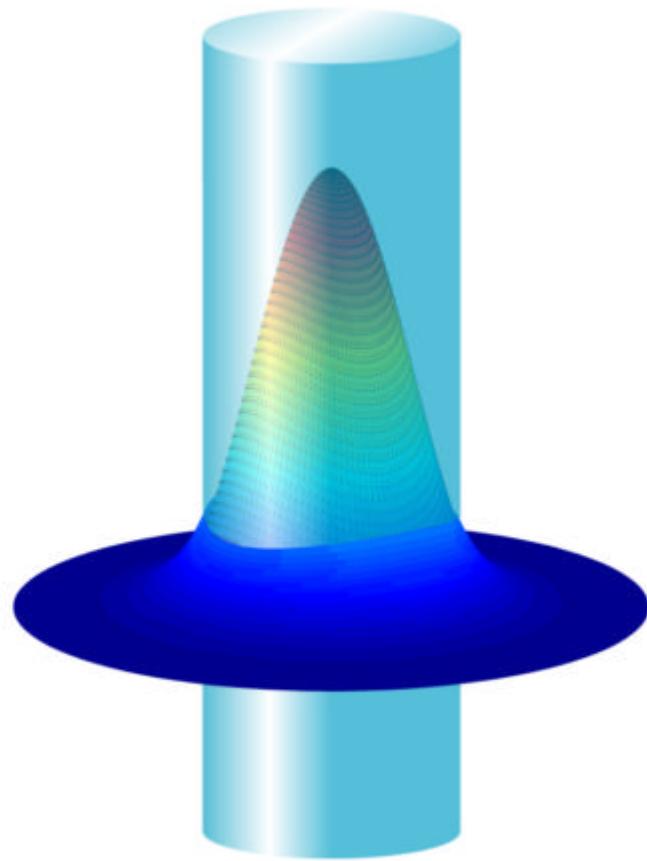
Manipulating light at the nanoscale

Poynting vector profile for 500-nm nanowire



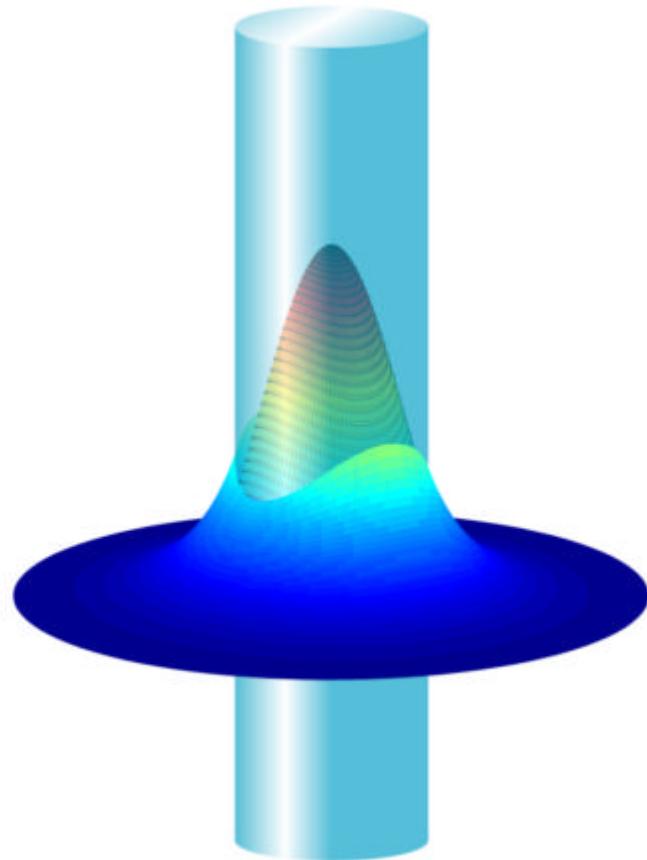
Manipulating light at the nanoscale

Poynting vector profile for 400-nm nanowire



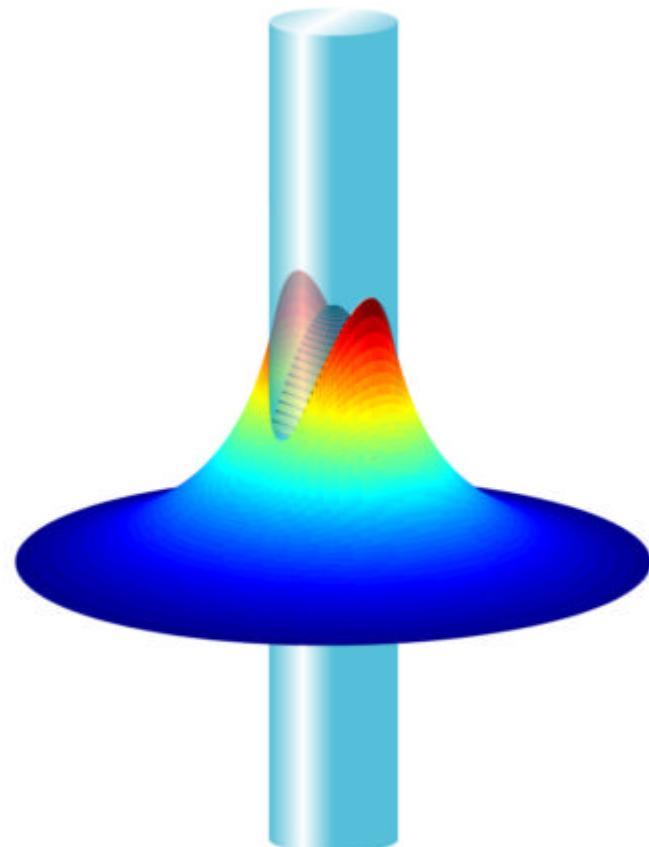
Manipulating light at the nanoscale

Poynting vector profile for 300-nm nanowire



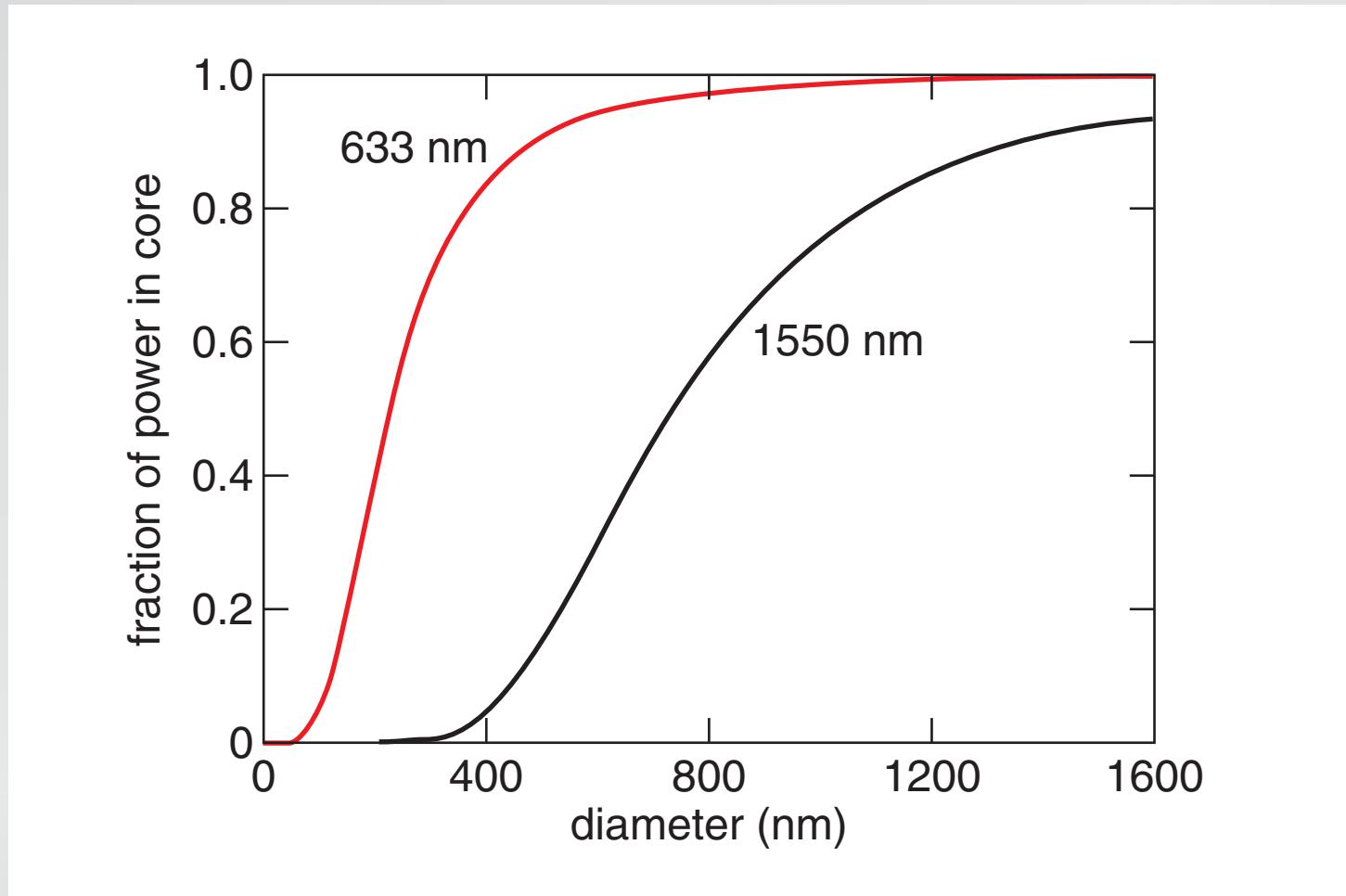
Manipulating light at the nanoscale

Poynting vector profile for 200-nm nanowire



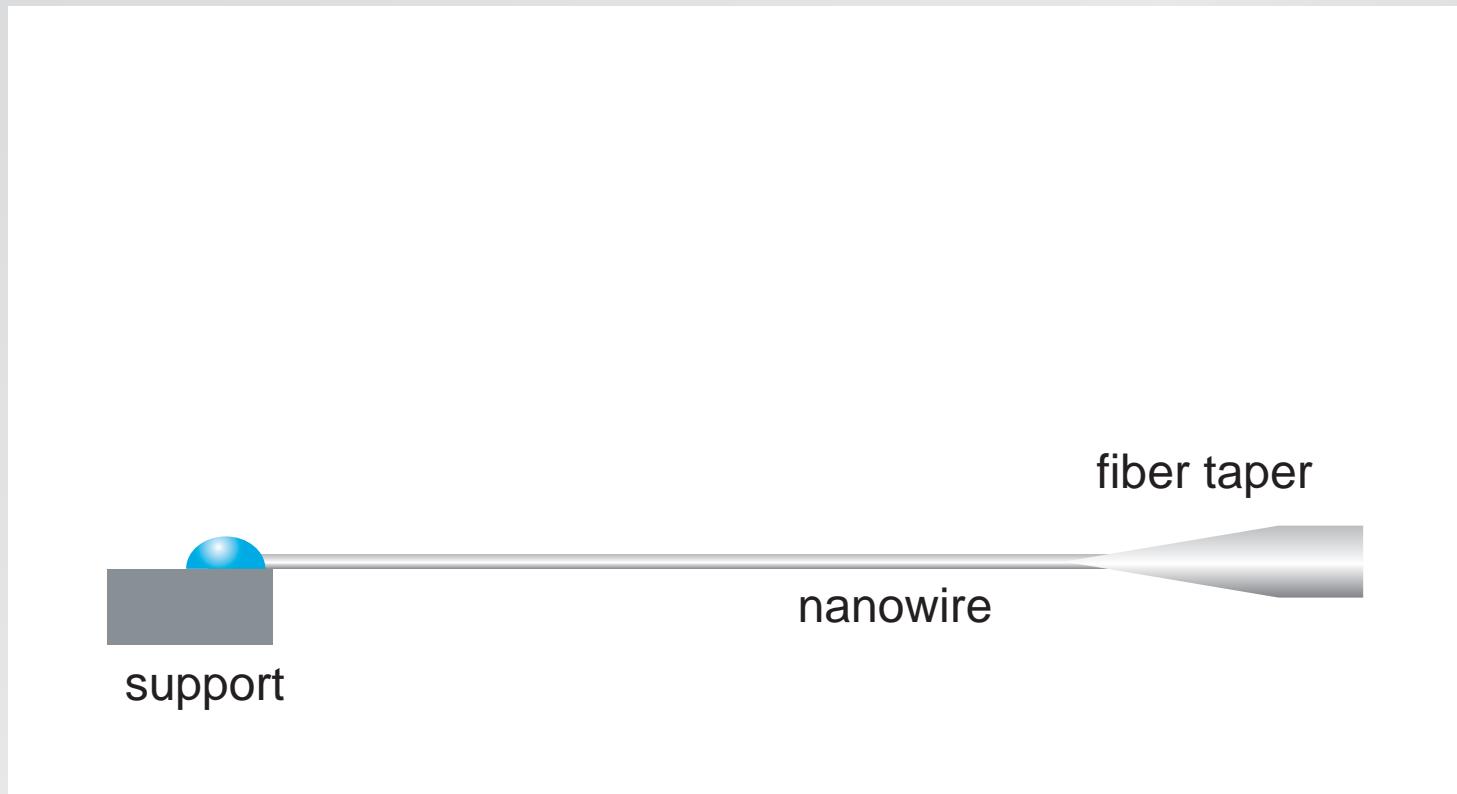
Manipulating light at the nanoscale

fraction of power carried in core



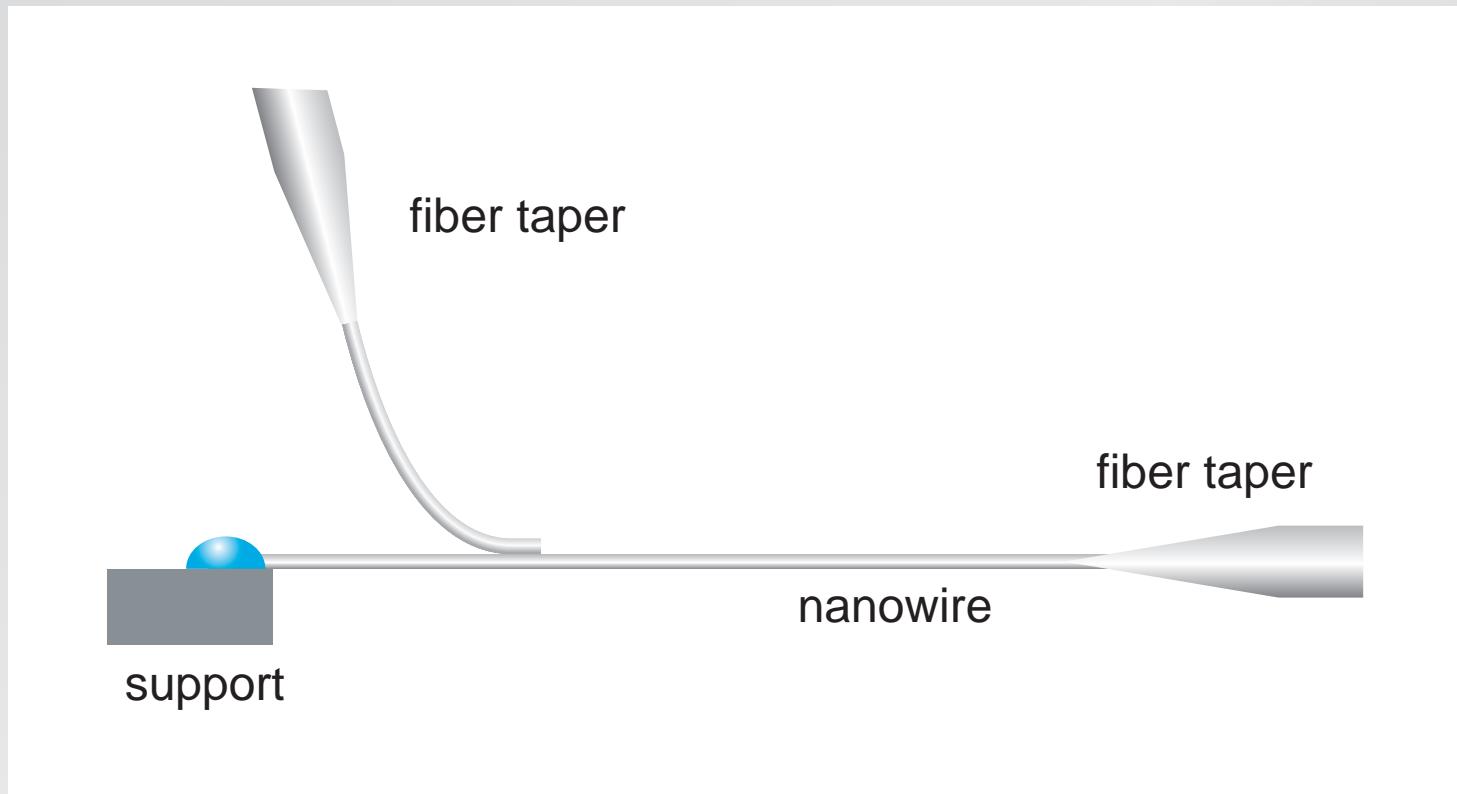
Manipulating light at the nanoscale

coupling light between nanowires



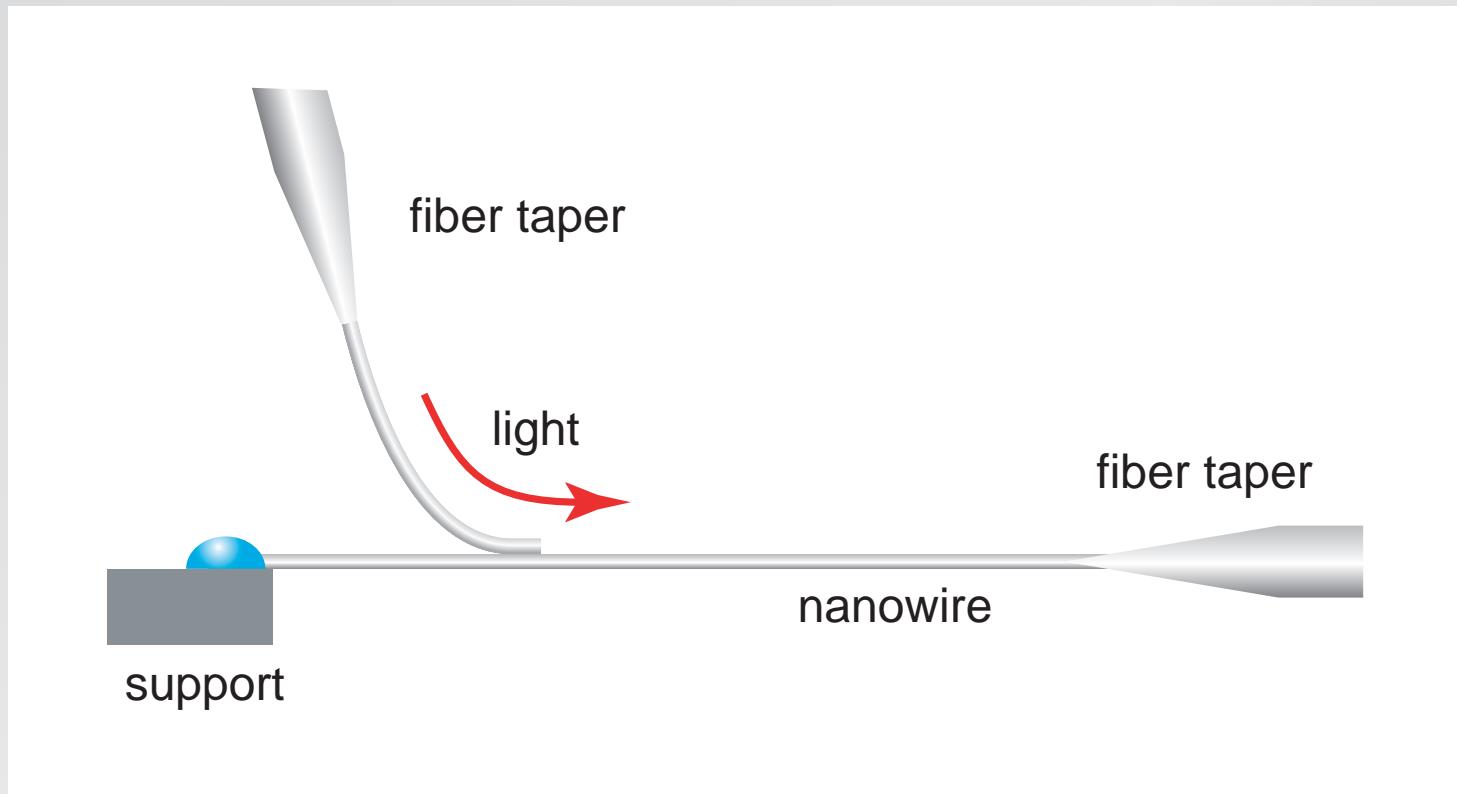
Manipulating light at the nanoscale

coupling light between nanowires



Manipulating light at the nanoscale

coupling light between nanowires



Manipulating light at the nanoscale

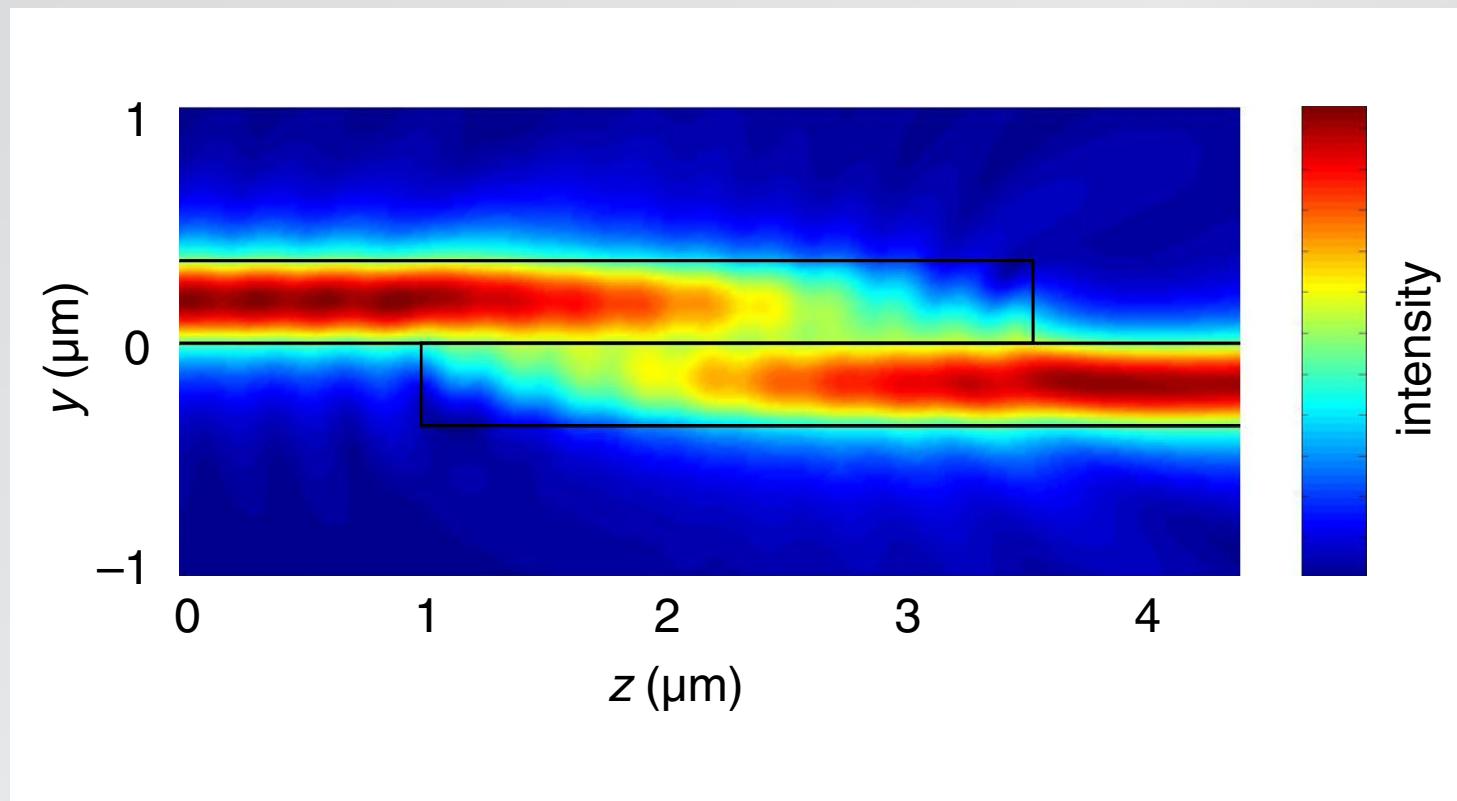
50µm

Manipulating light at the nanoscale

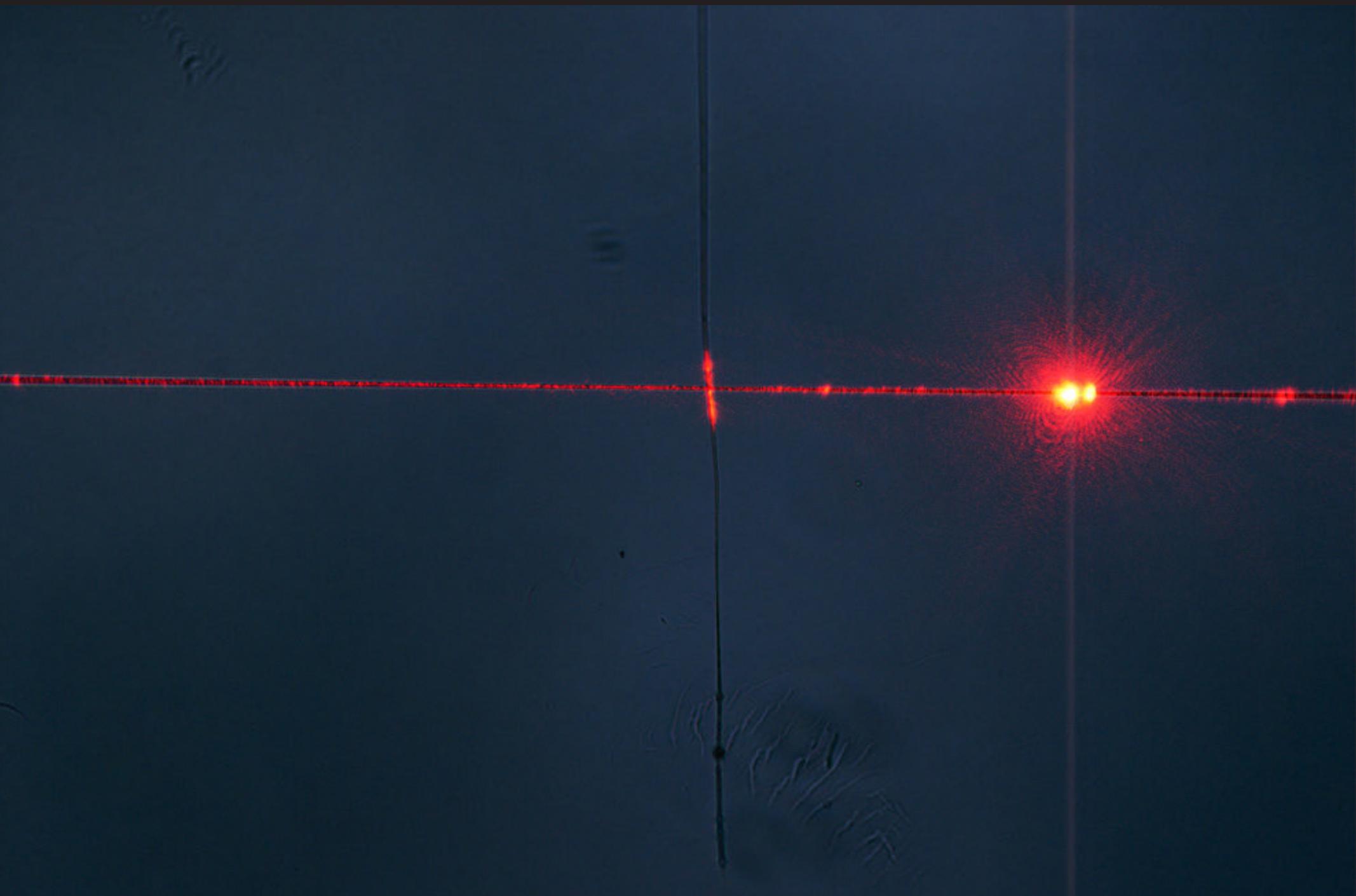


Manipulating light at the nanoscale

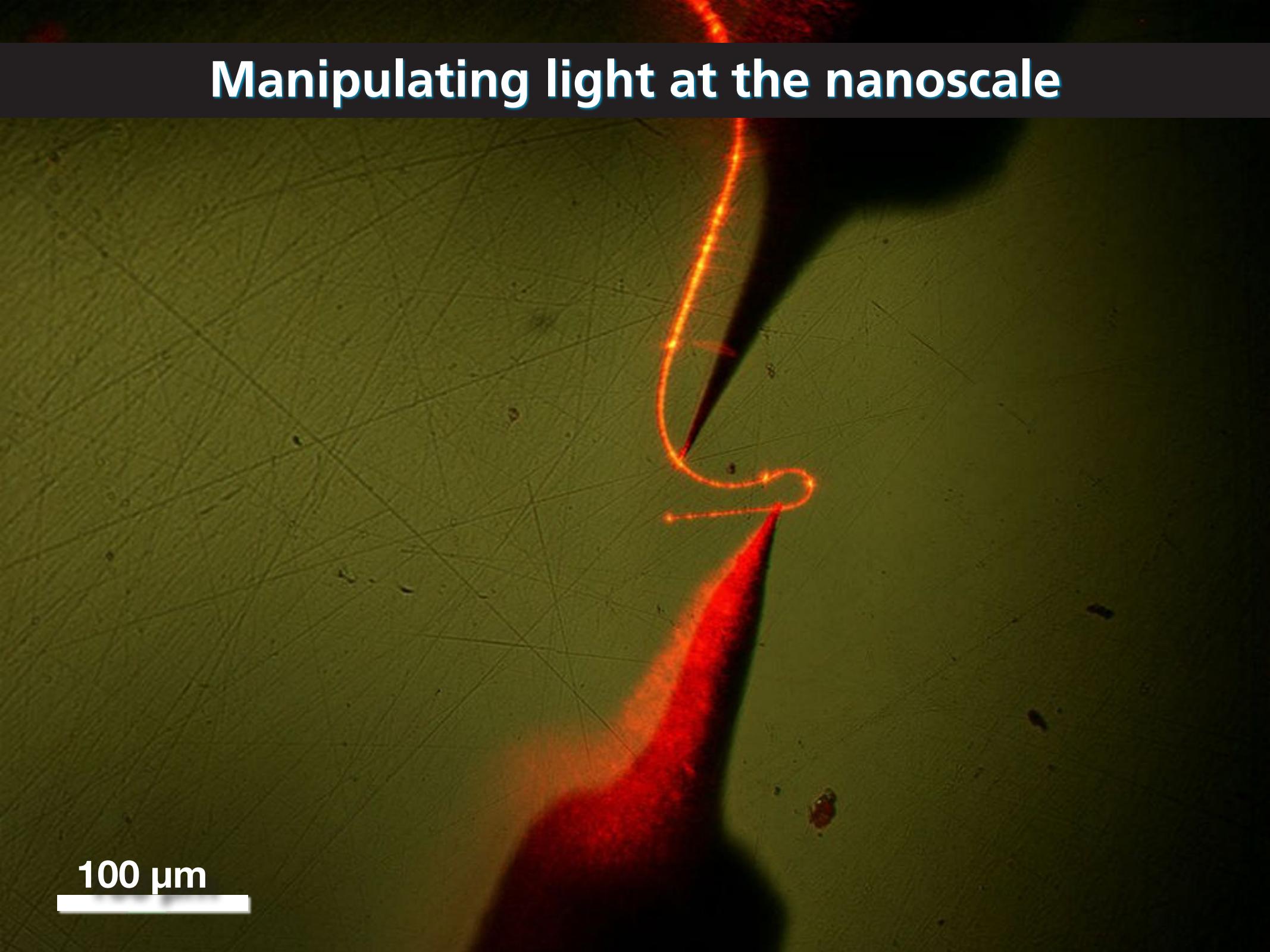
intensity distribution



Manipulating light at the nanoscale

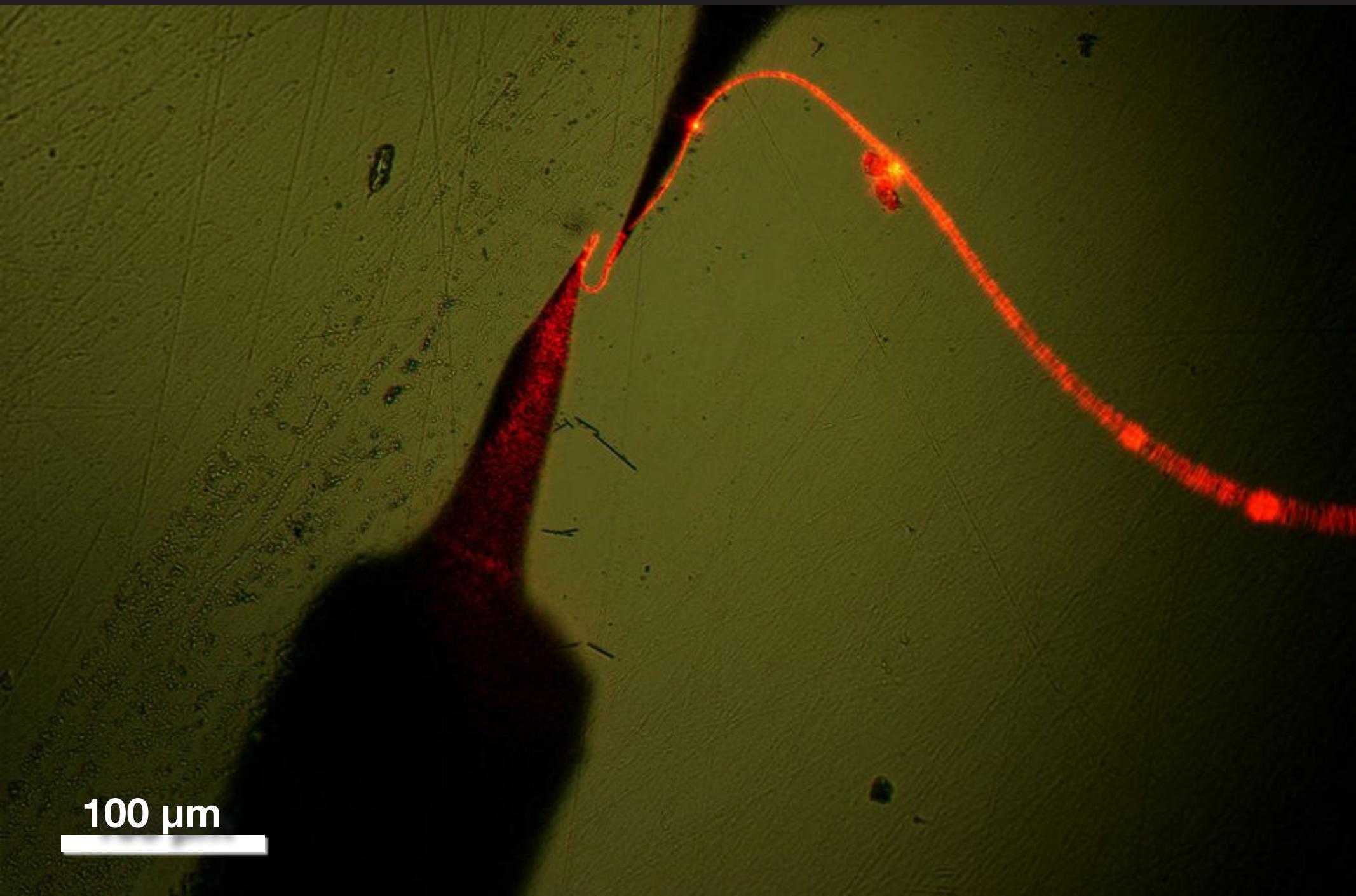


Manipulating light at the nanoscale



100 μm

Manipulating light at the nanoscale



100 μm

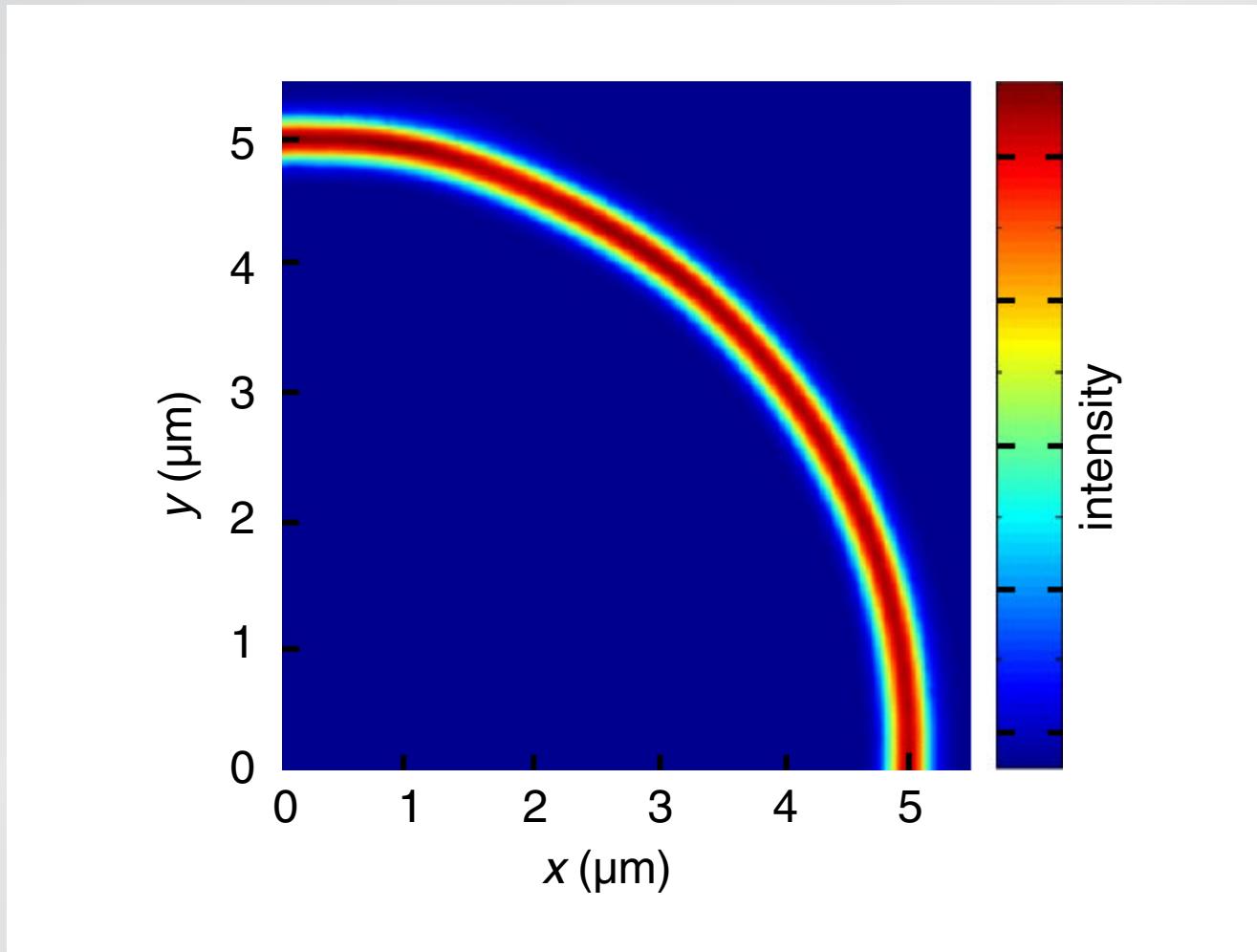
Manipulating light at the nanoscale

minimum bending
radius: $5.6 \mu\text{m}$

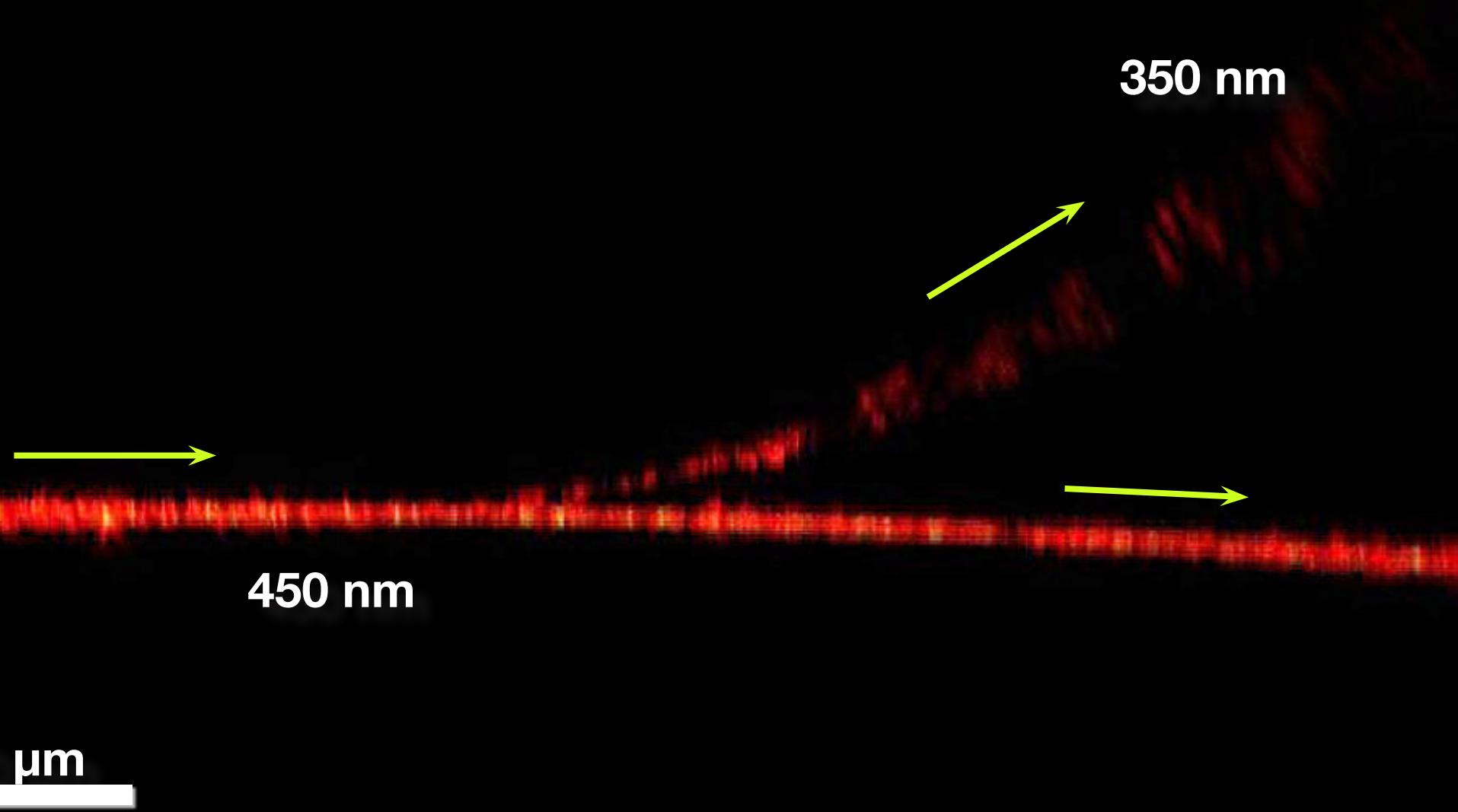
100 μm

Manipulating light at the nanoscale

virtually no loss through 5 μm corner!



Manipulating light at the nanoscale

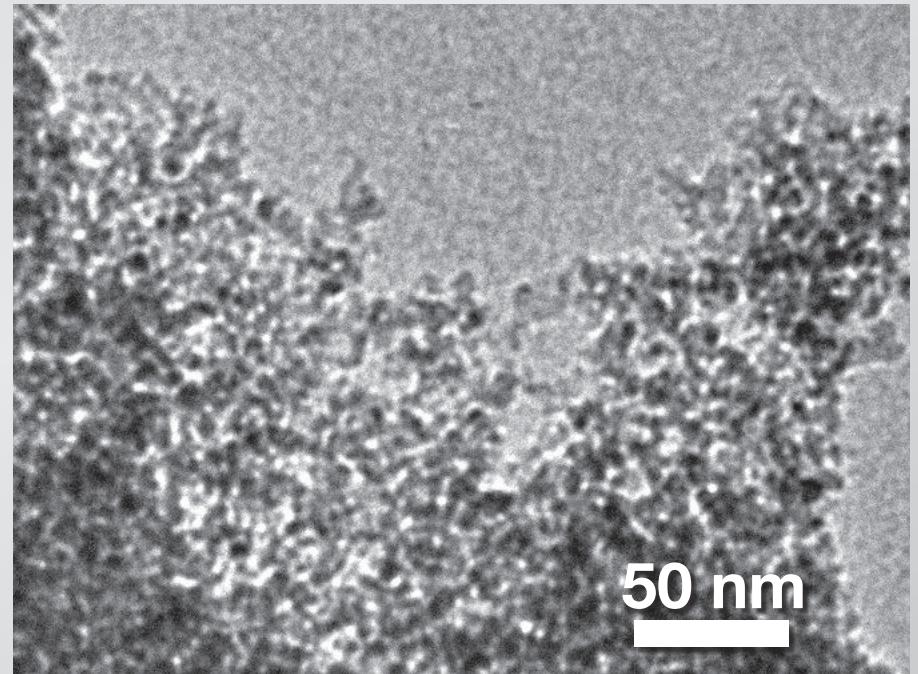
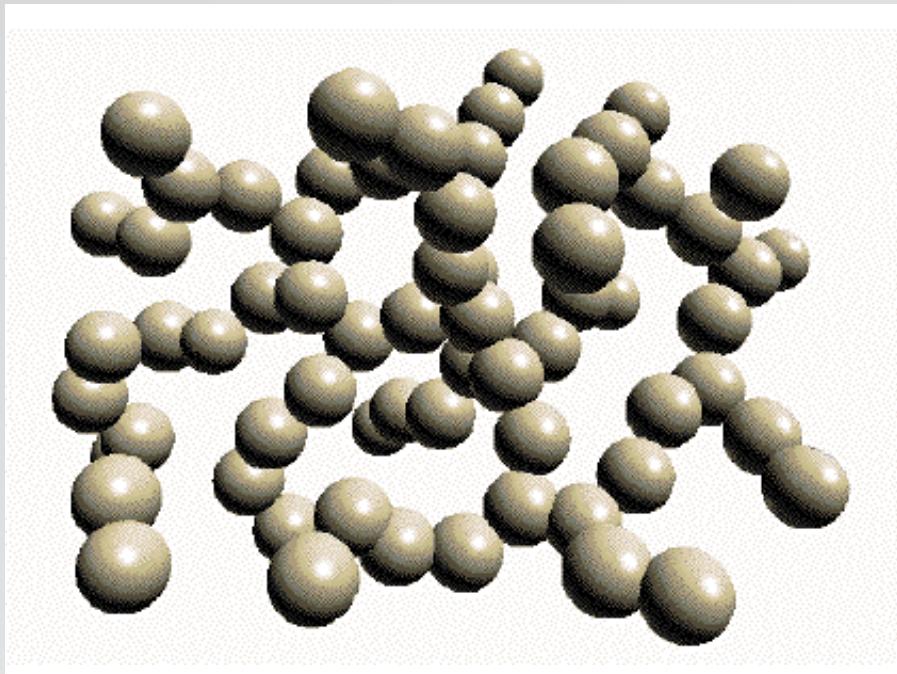


Manipulating light at the nanoscale



Manipulating light at the nanoscale

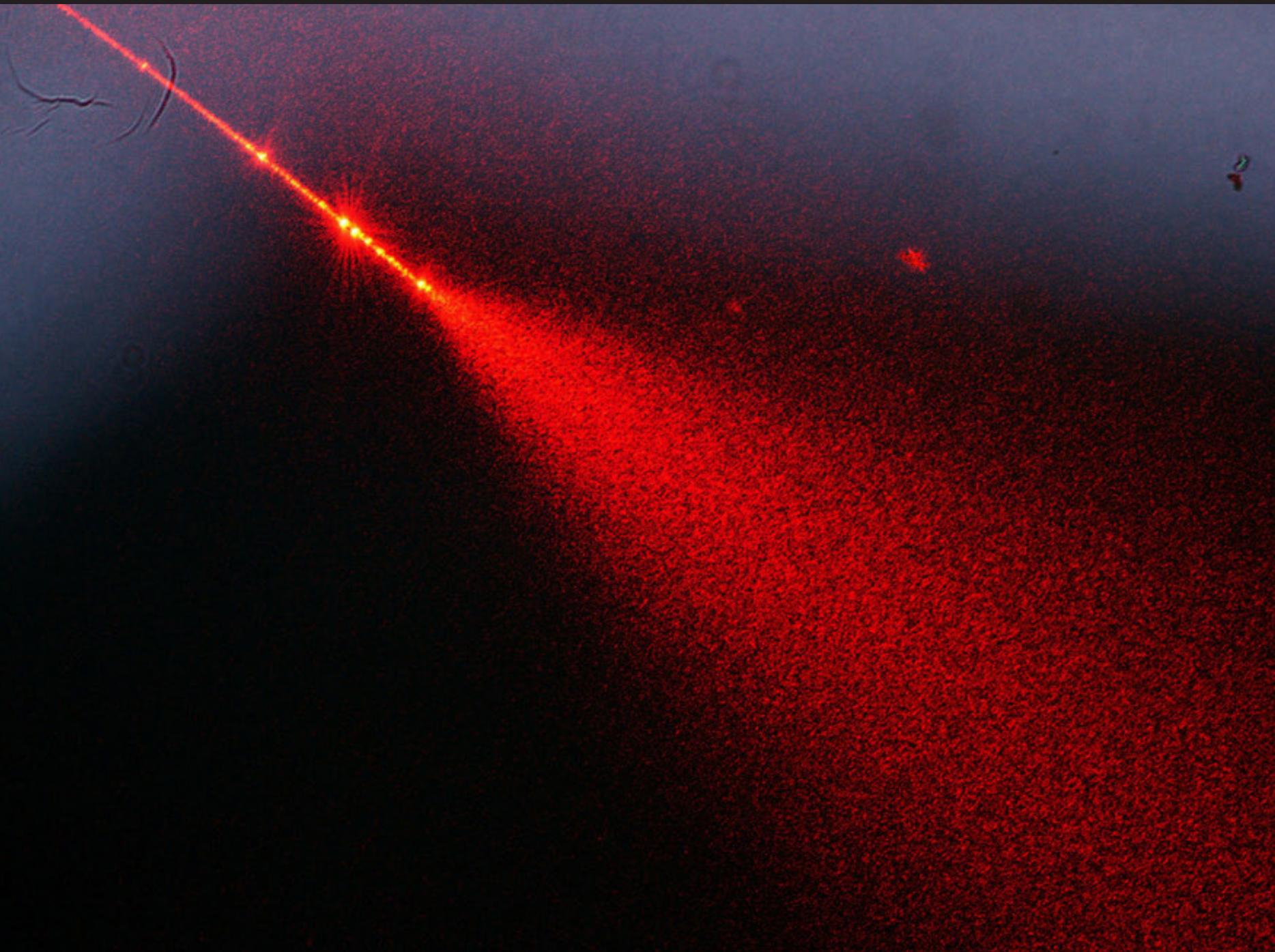
Aerogel



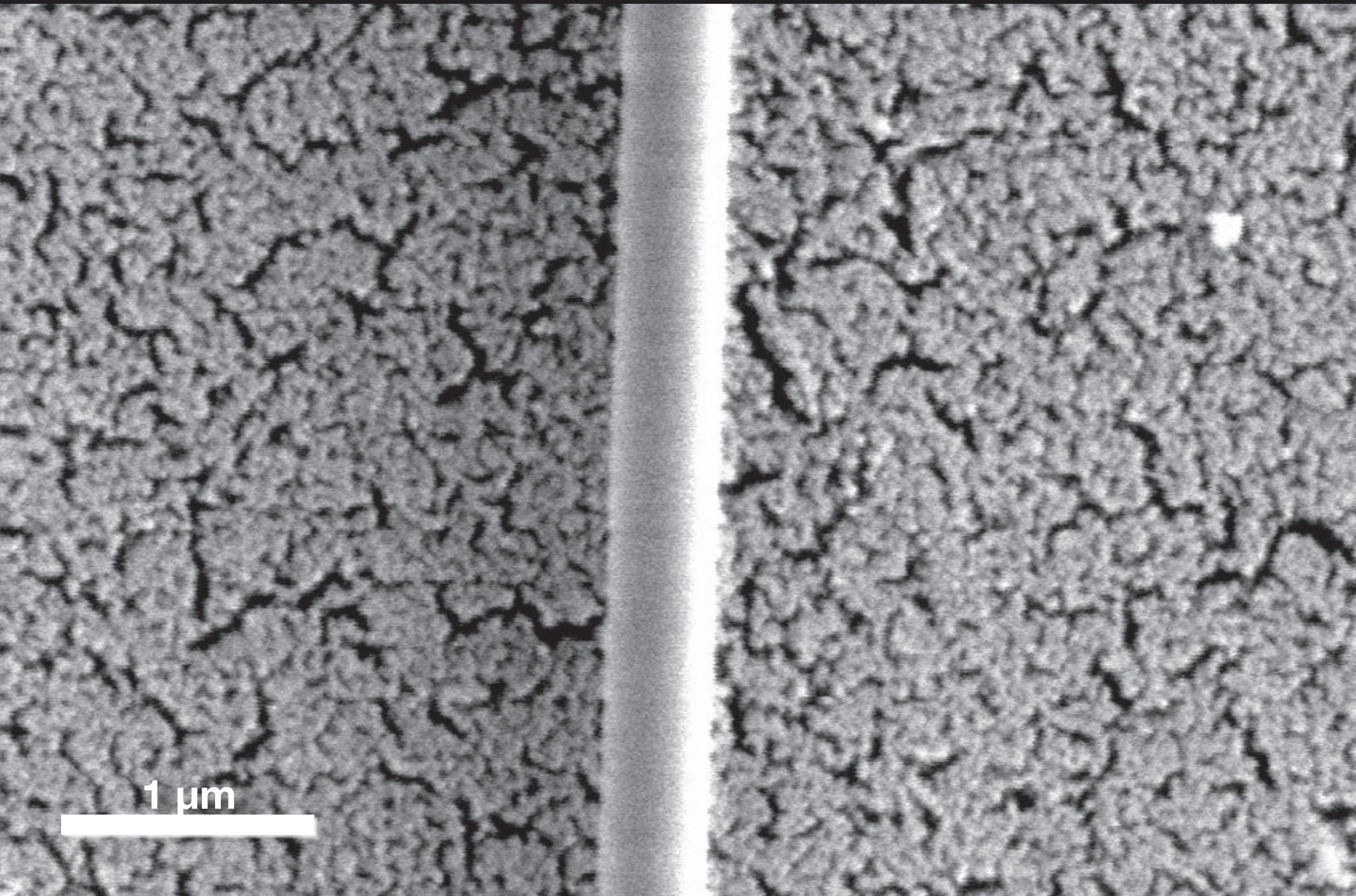
density: 1.9 kg/m^3

index of refraction: 1.03–1.08

Manipulating light at the nanoscale



Manipulating light at the nanoscale



Manipulating light at the nanoscale

530 nm

50 μ m

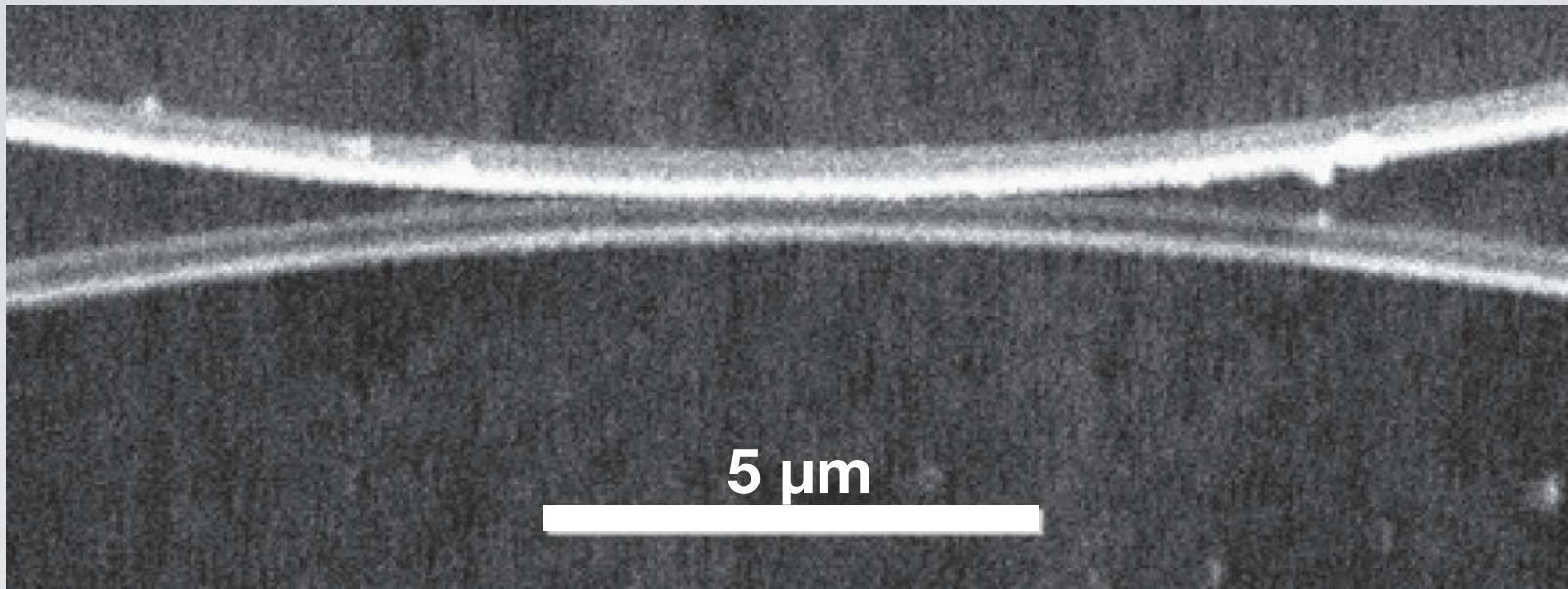
Manipulating light at the nanoscale

420 nm

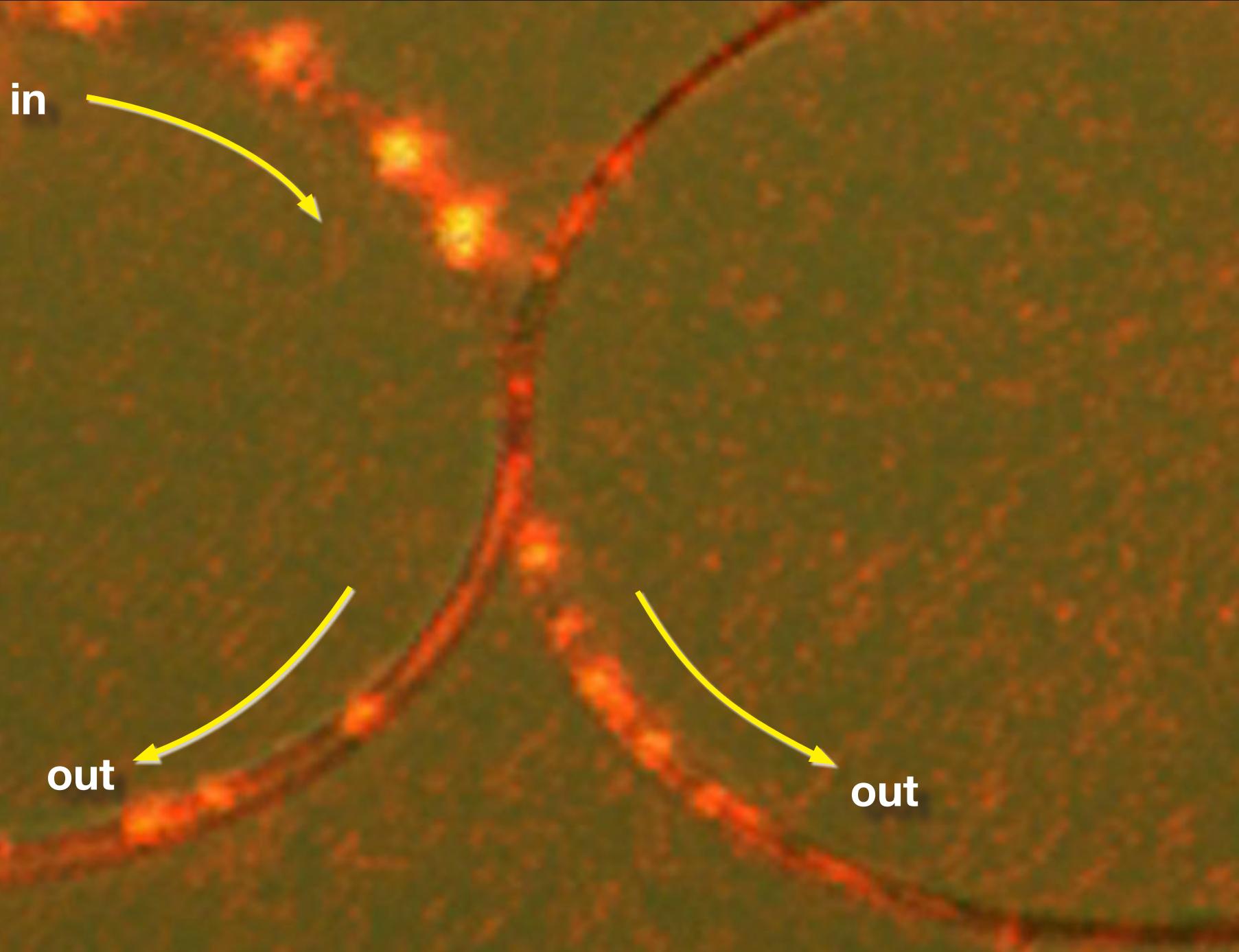
420 nm

aerogel

Manipulating light at the nanoscale



Manipulating light at the nanoscale



Manipulating light at the nanoscale

use tapered fibers to couple light to nanoscale objects

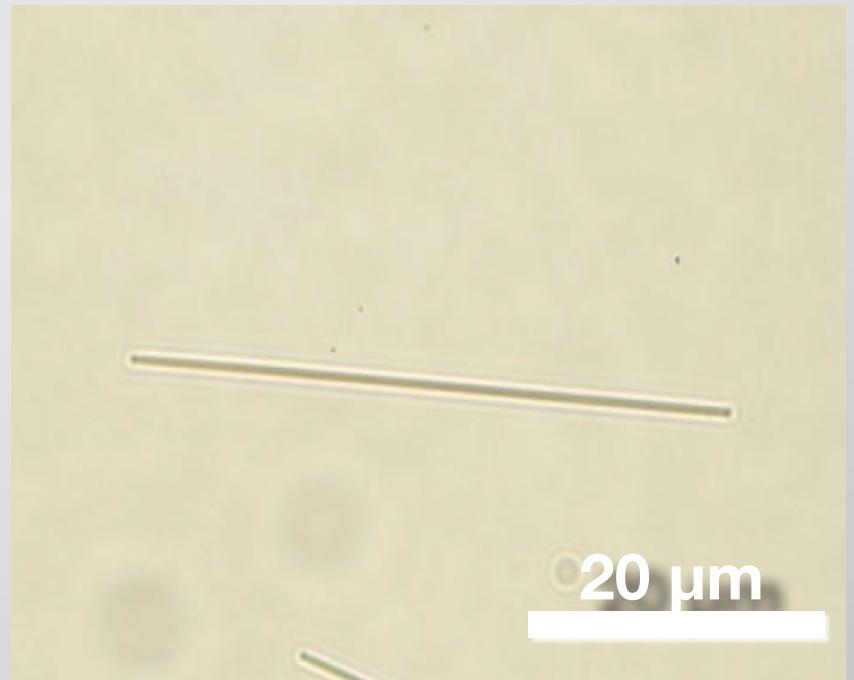
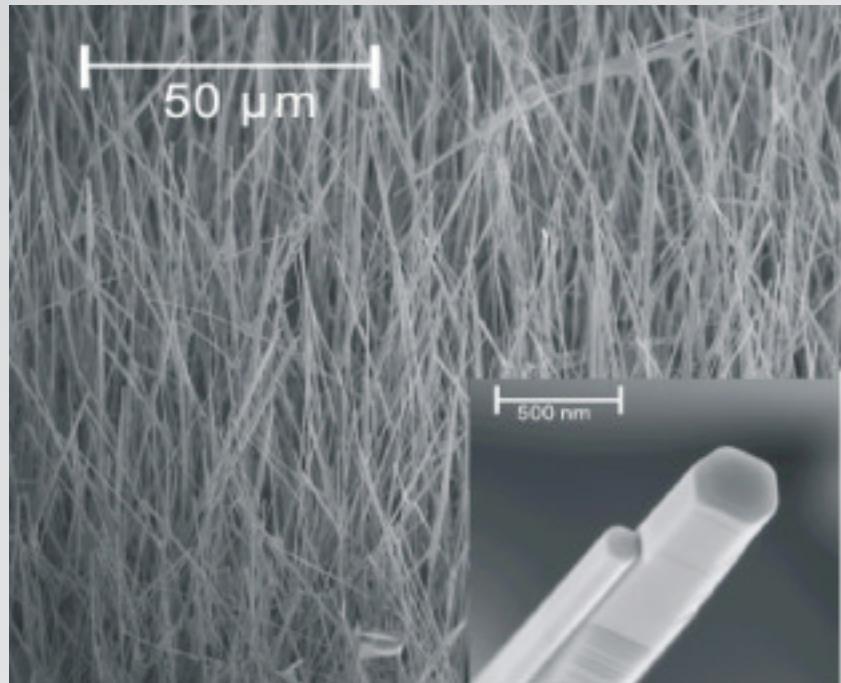
Manipulating light at the nanoscale



ZnO:non-toxic, wide bandgap semiconductor

Manipulating light at the nanoscale

vapor transport grown ZnO nanowires



80–400 nm diameter, up to 80 μm long

Manipulating light at the nanoscale

best of both worlds

ZnO

silica

bottom-up

top-down

semiconductor

glass

active photonic devices

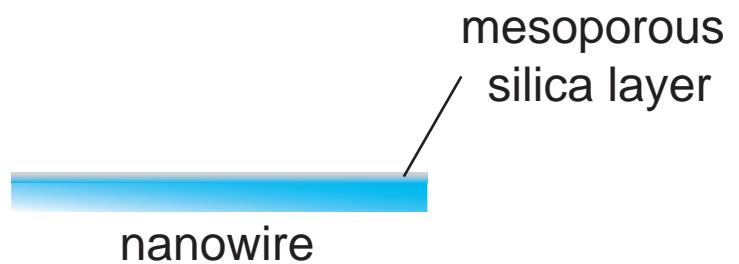
passive waveguides

electrical operation

link to macroworld

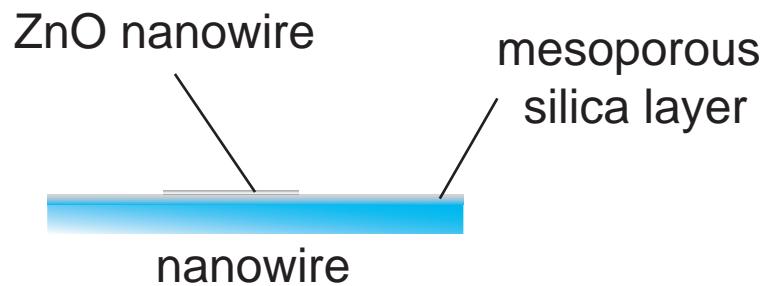
Manipulating light at the nanoscale

coupling to ZnO nanowires



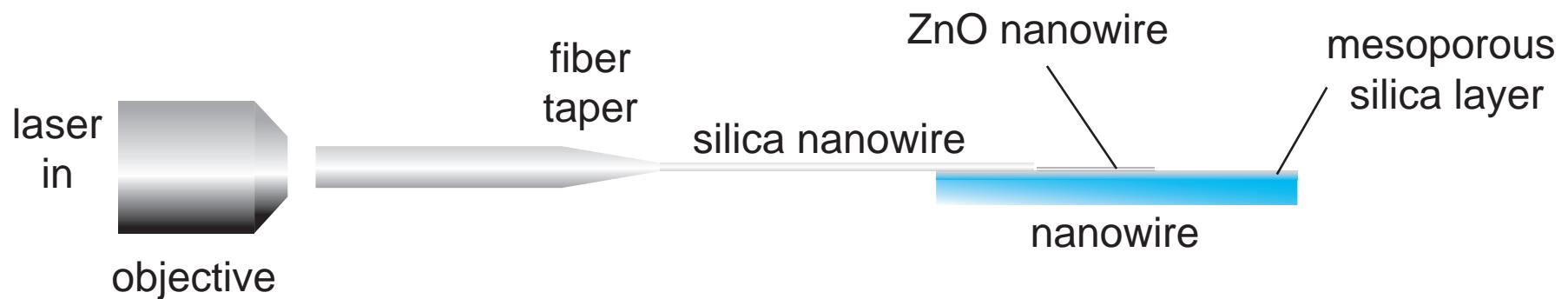
Manipulating light at the nanoscale

coupling to ZnO nanowires



Manipulating light at the nanoscale

coupling to ZnO nanowires

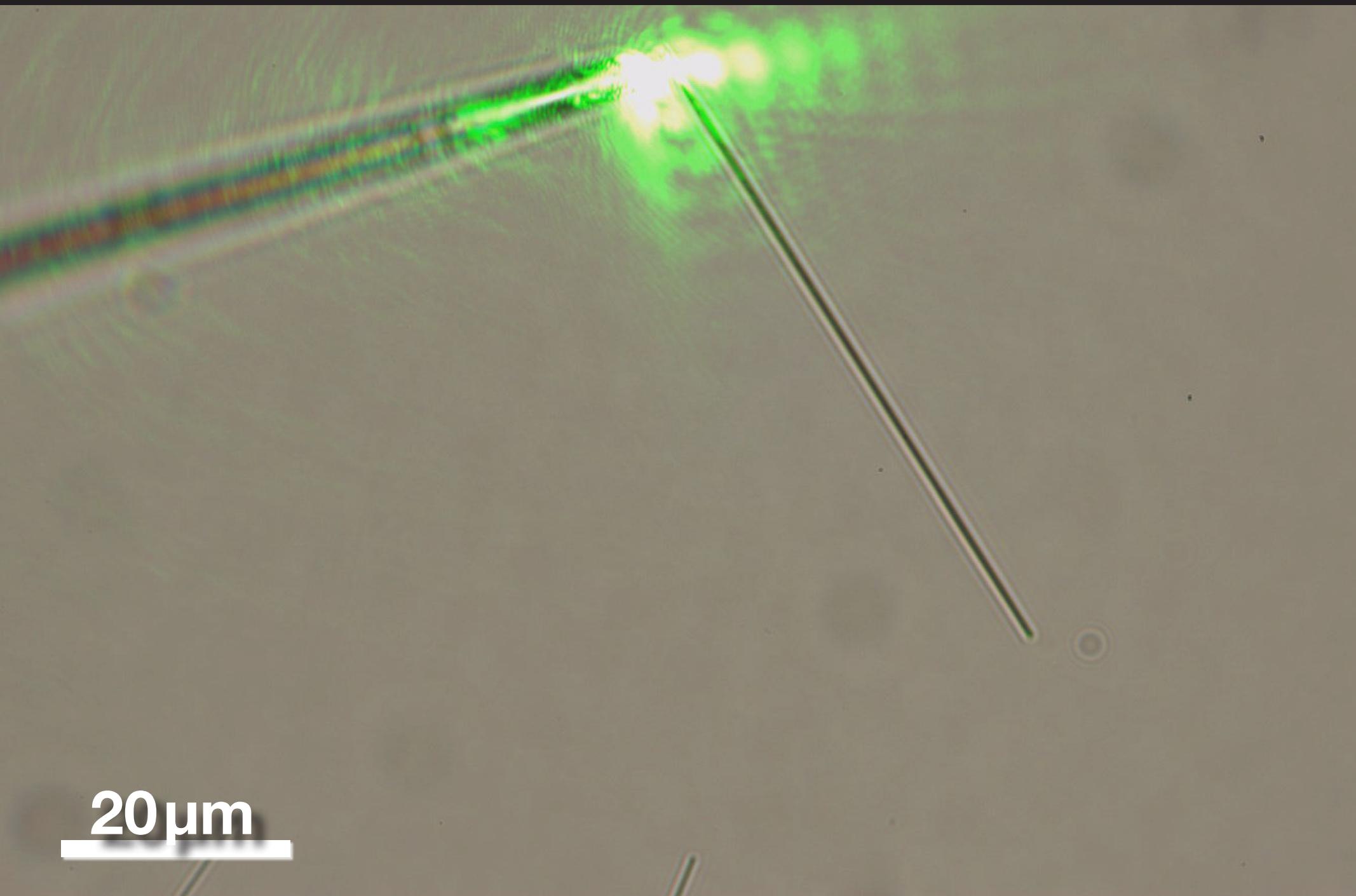


Manipulating light at the nanoscale

coupling to ZnO nanowires

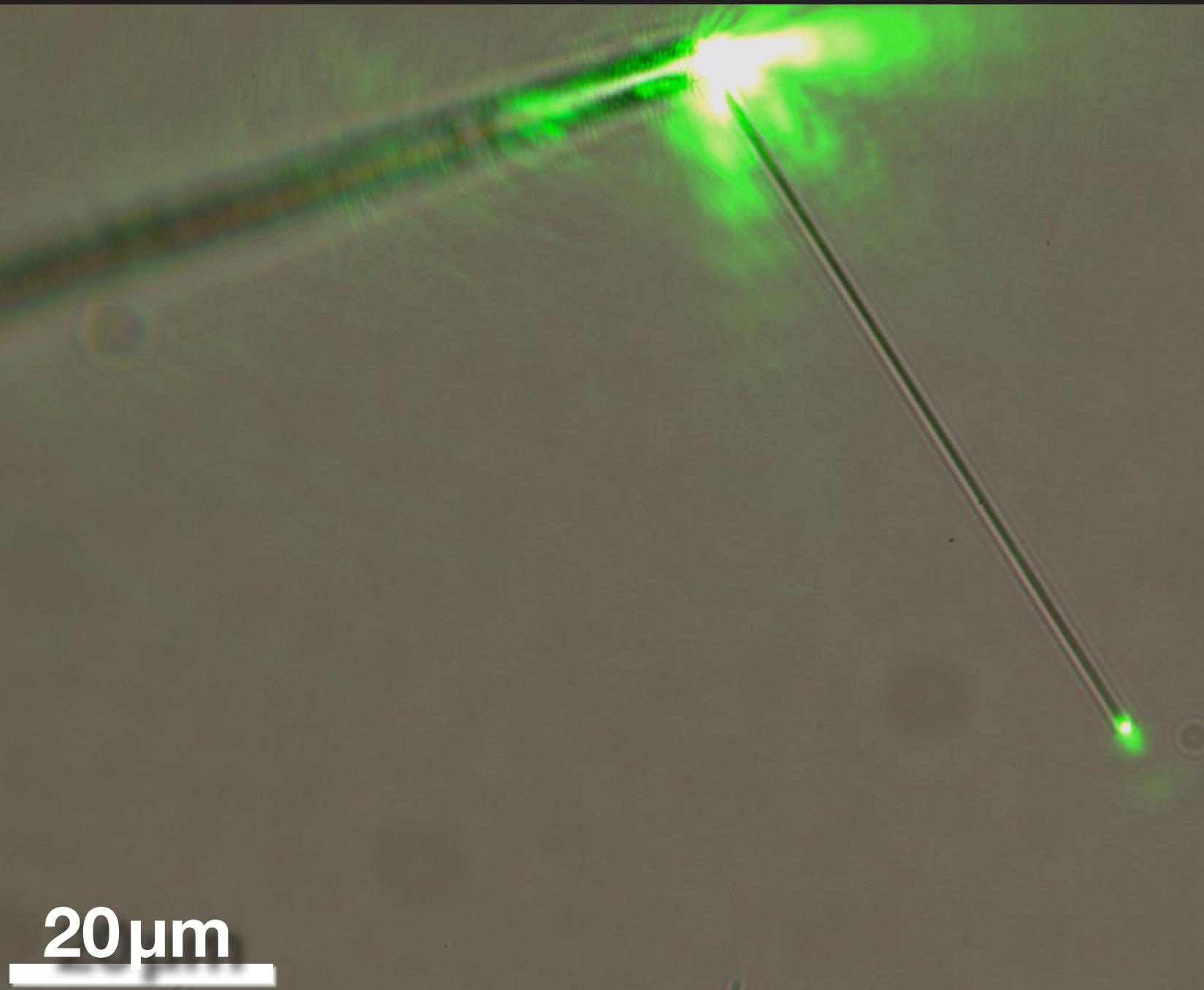


Manipulating light at the nanoscale

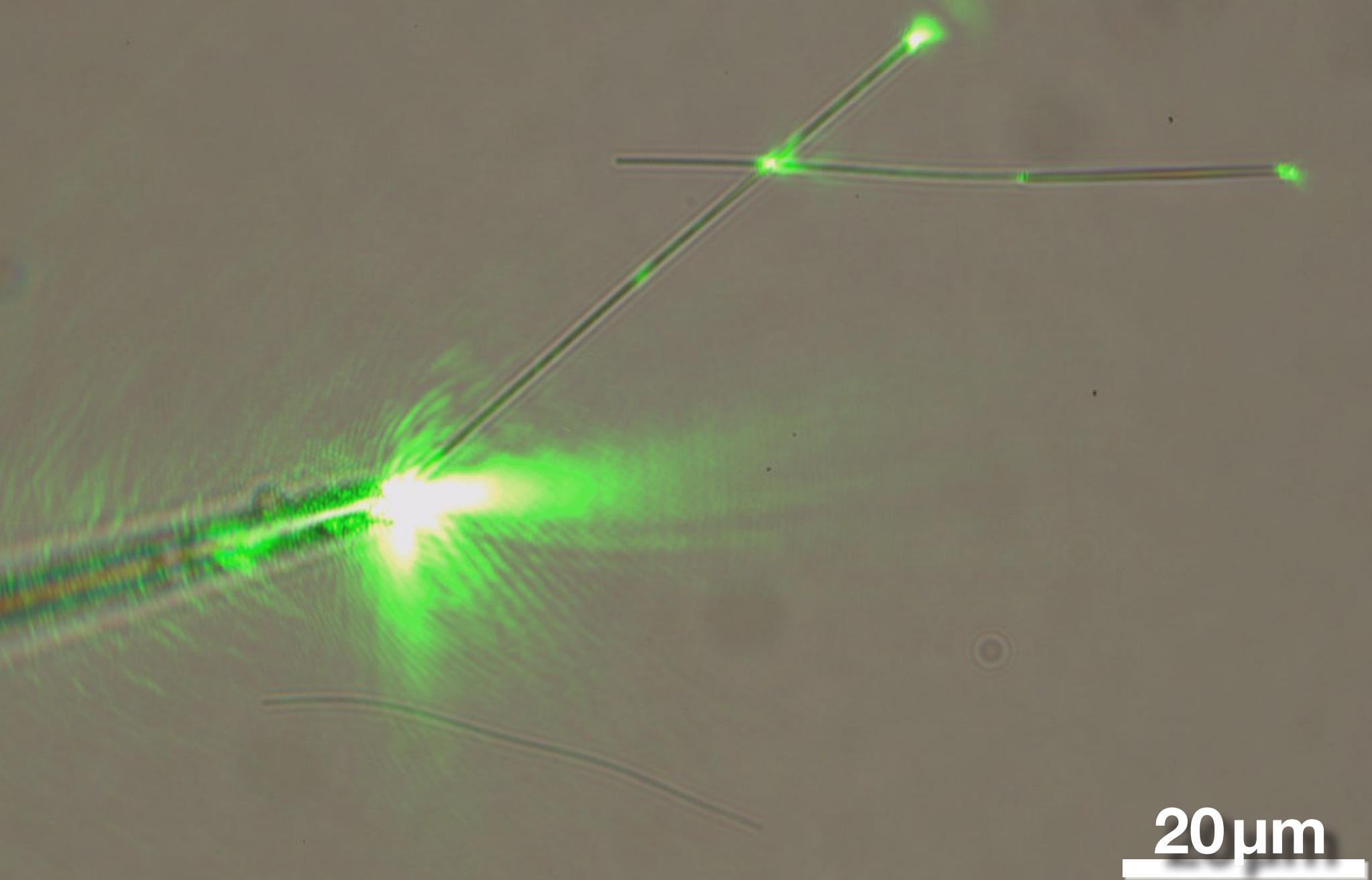


20 μ m

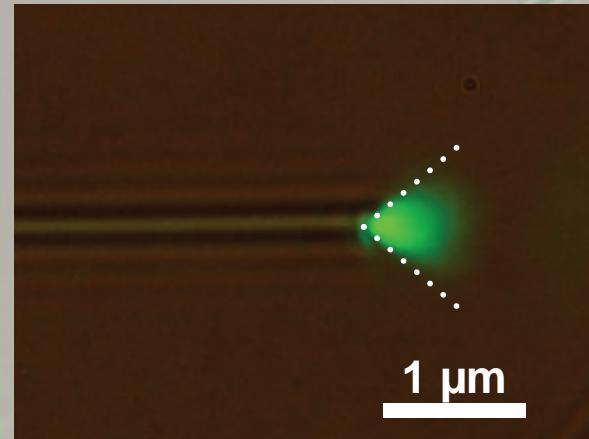
Manipulating light at the nanoscale



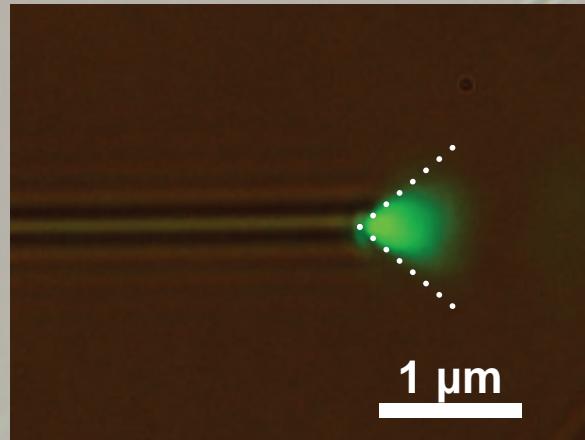
Manipulating light at the nanoscale



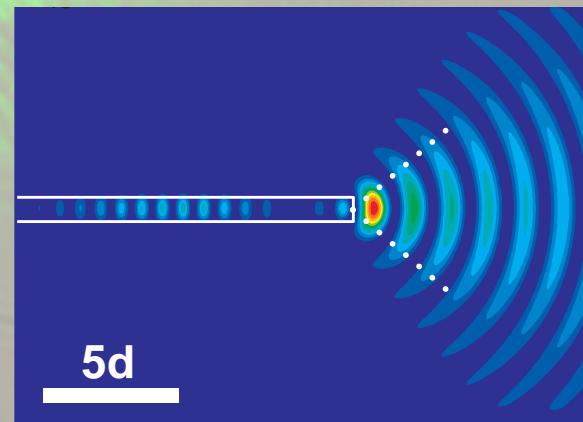
Manipulating light at the nanoscale



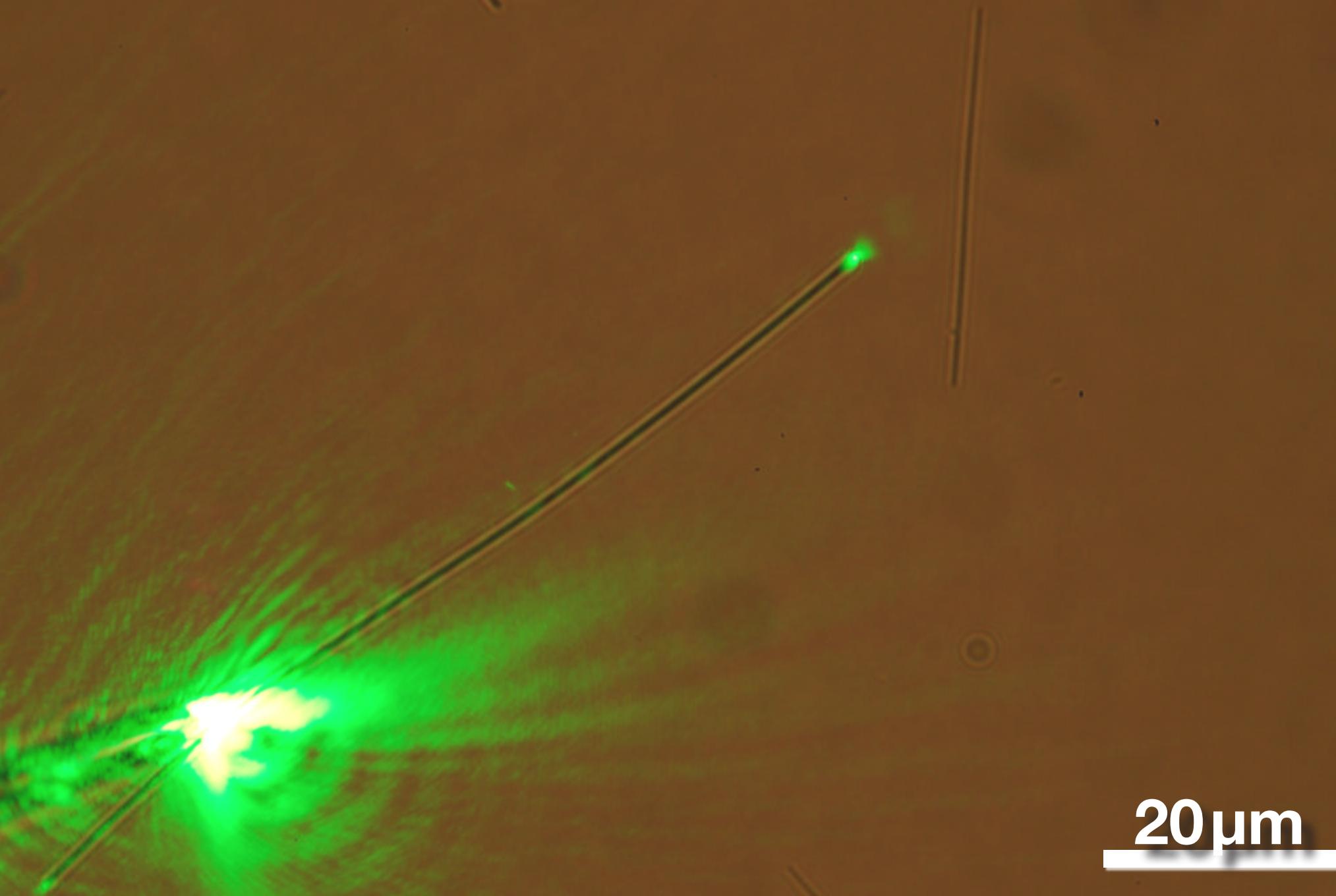
Manipulating light at the nanoscale



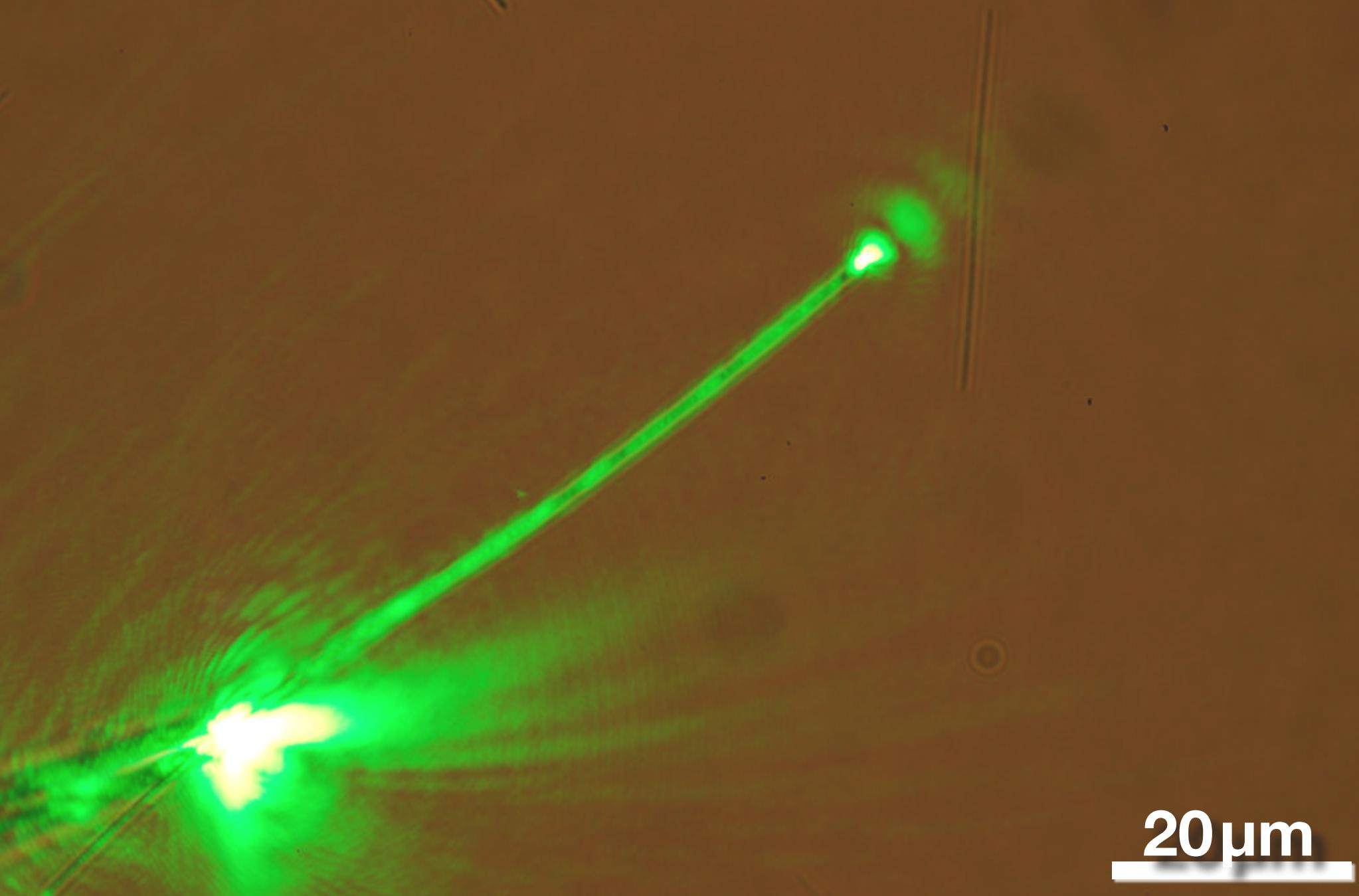
FDTD simulation



Manipulating light at the nanoscale

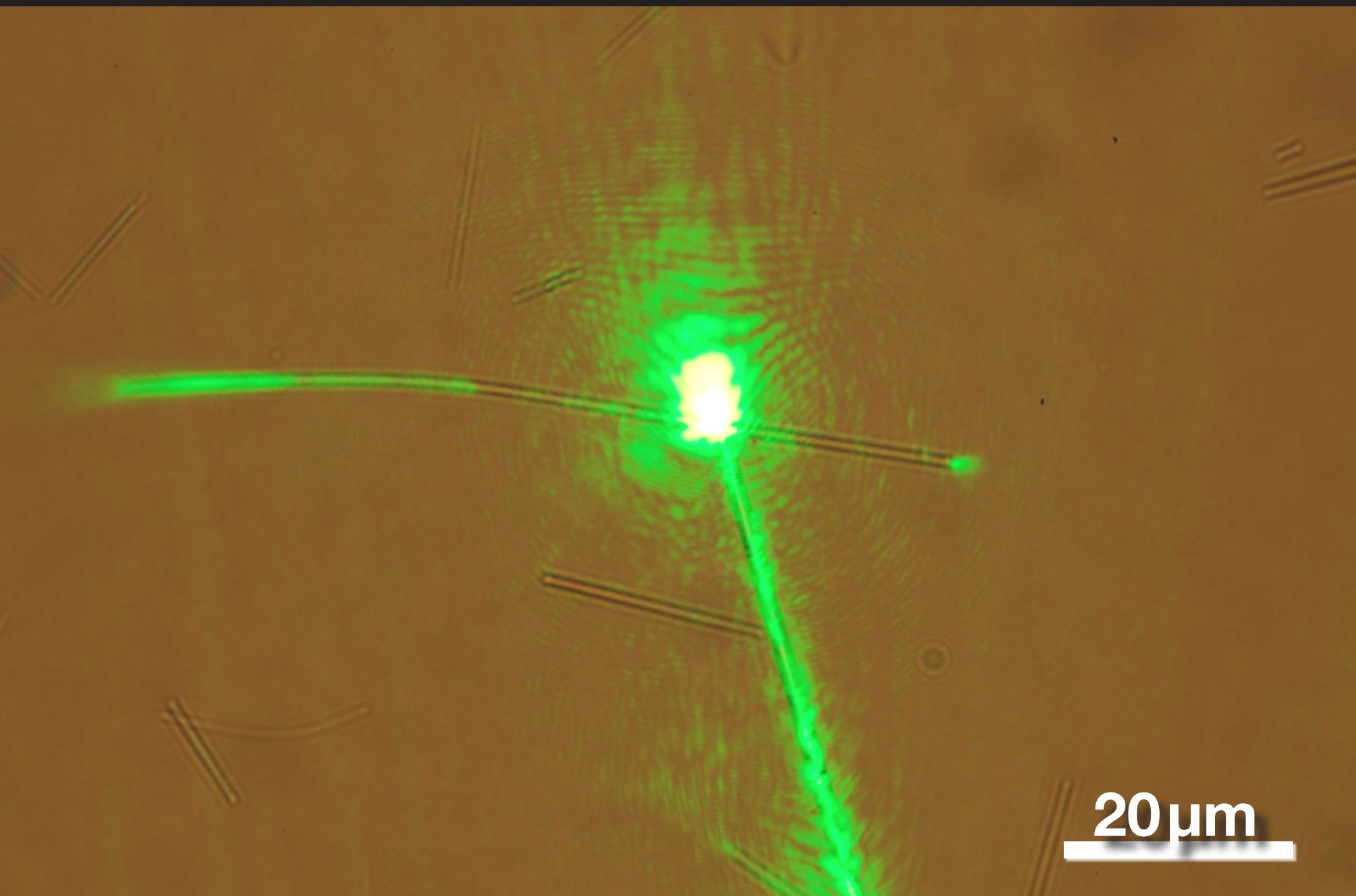


Manipulating light at the nanoscale



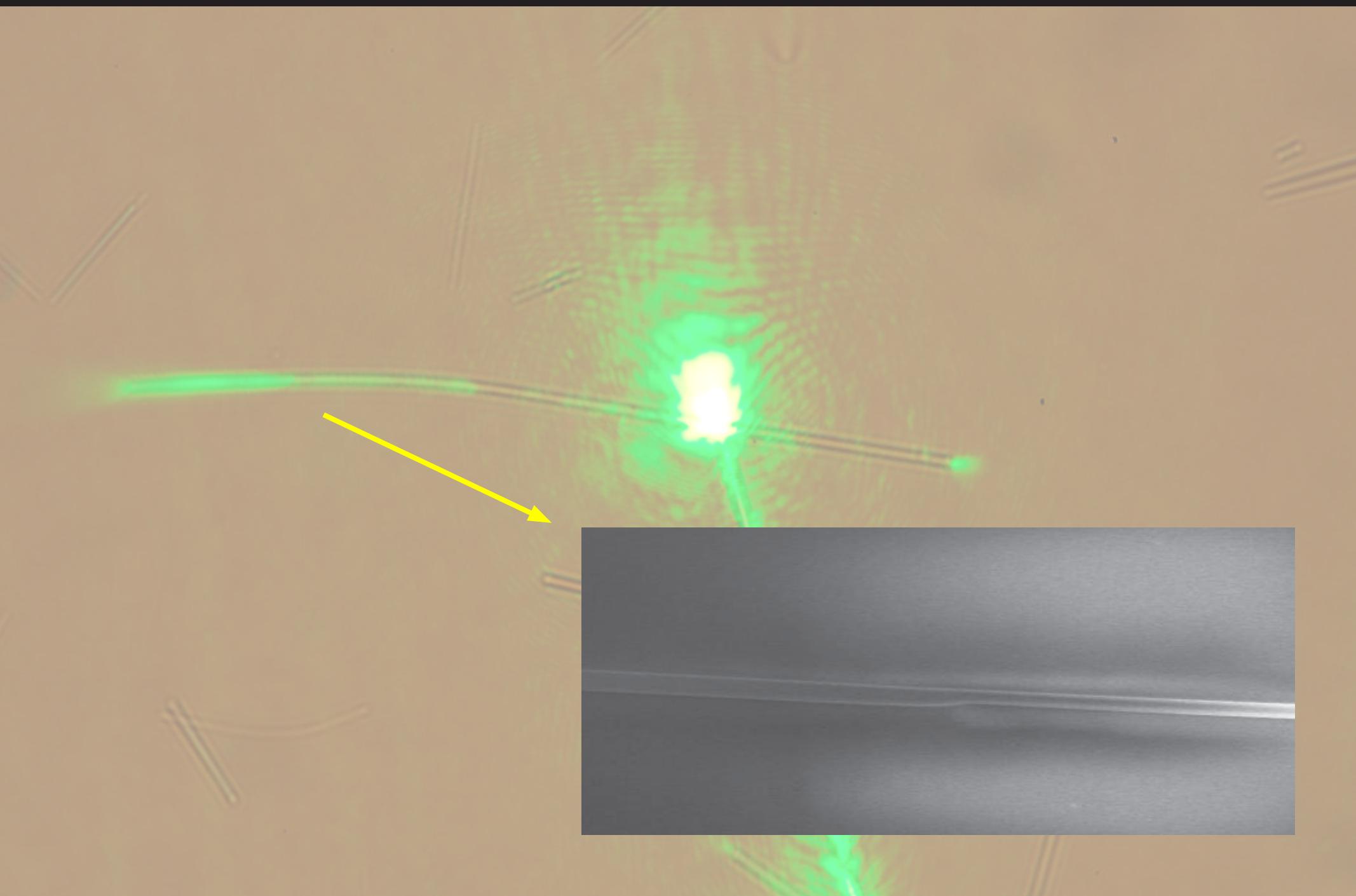
20 μ m

Manipulating light at the nanoscale



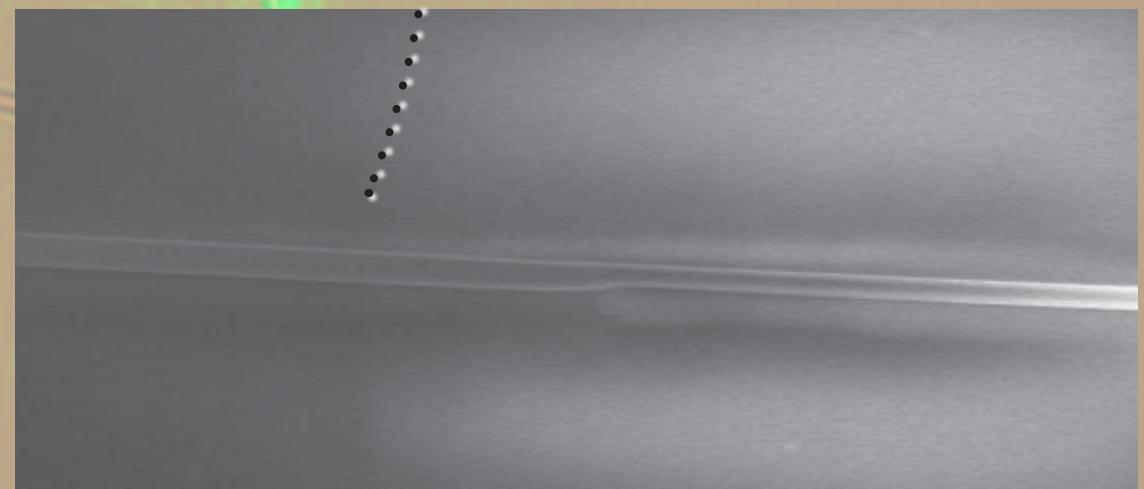
20 μ m

Manipulating light at the nanoscale



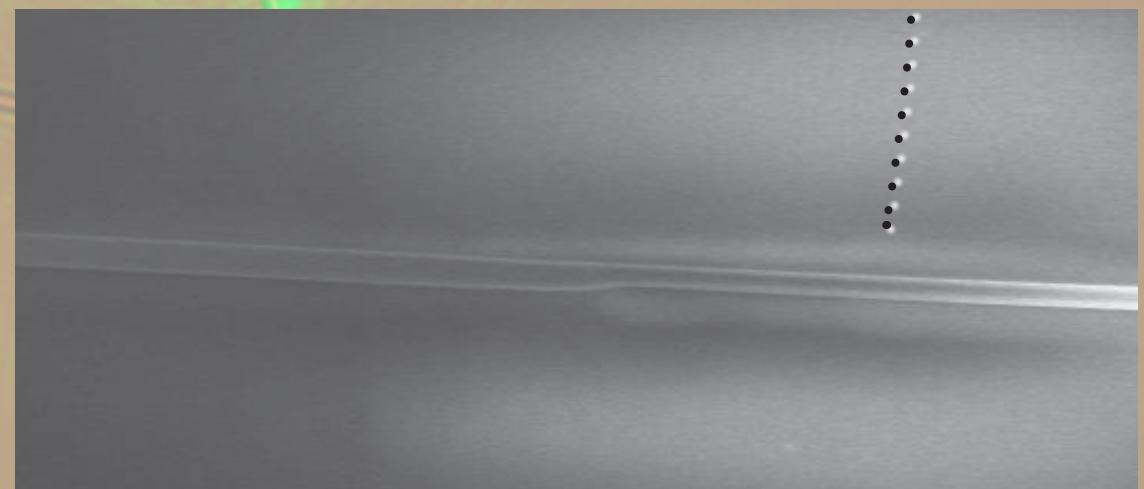
Manipulating light at the nanoscale

large diameter:
multimode



Manipulating light at the nanoscale

small diameter:
single mode



Manipulating light at the nanoscale

Points to keep in mind:

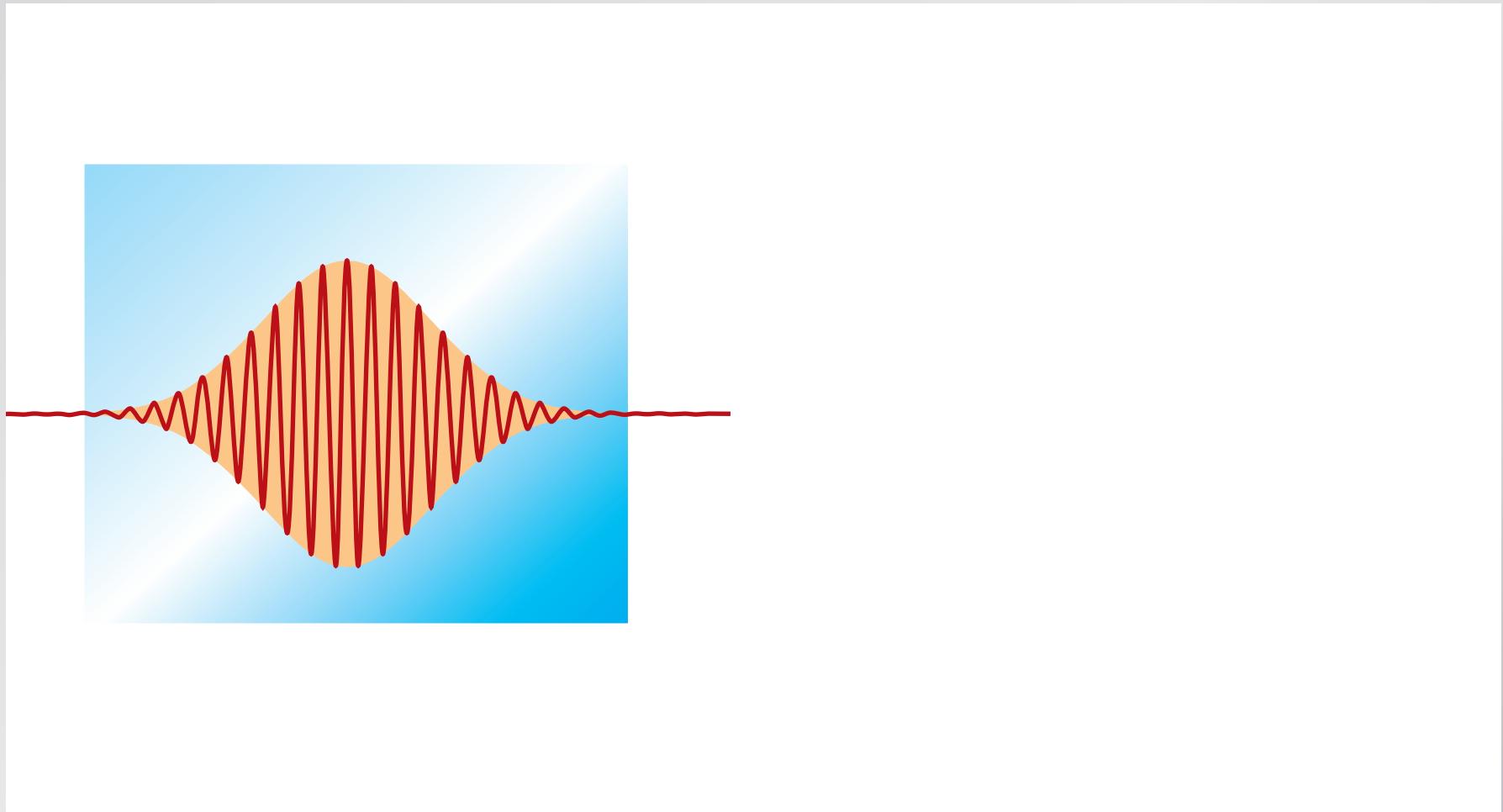
- **low loss**
- **large evanescent field**
- **convenient coupling to nanoscale**

Outline

- waveguiding
- silica nanowires
- manipulating light at the nanoscale
- nanoscale nonlinear optics

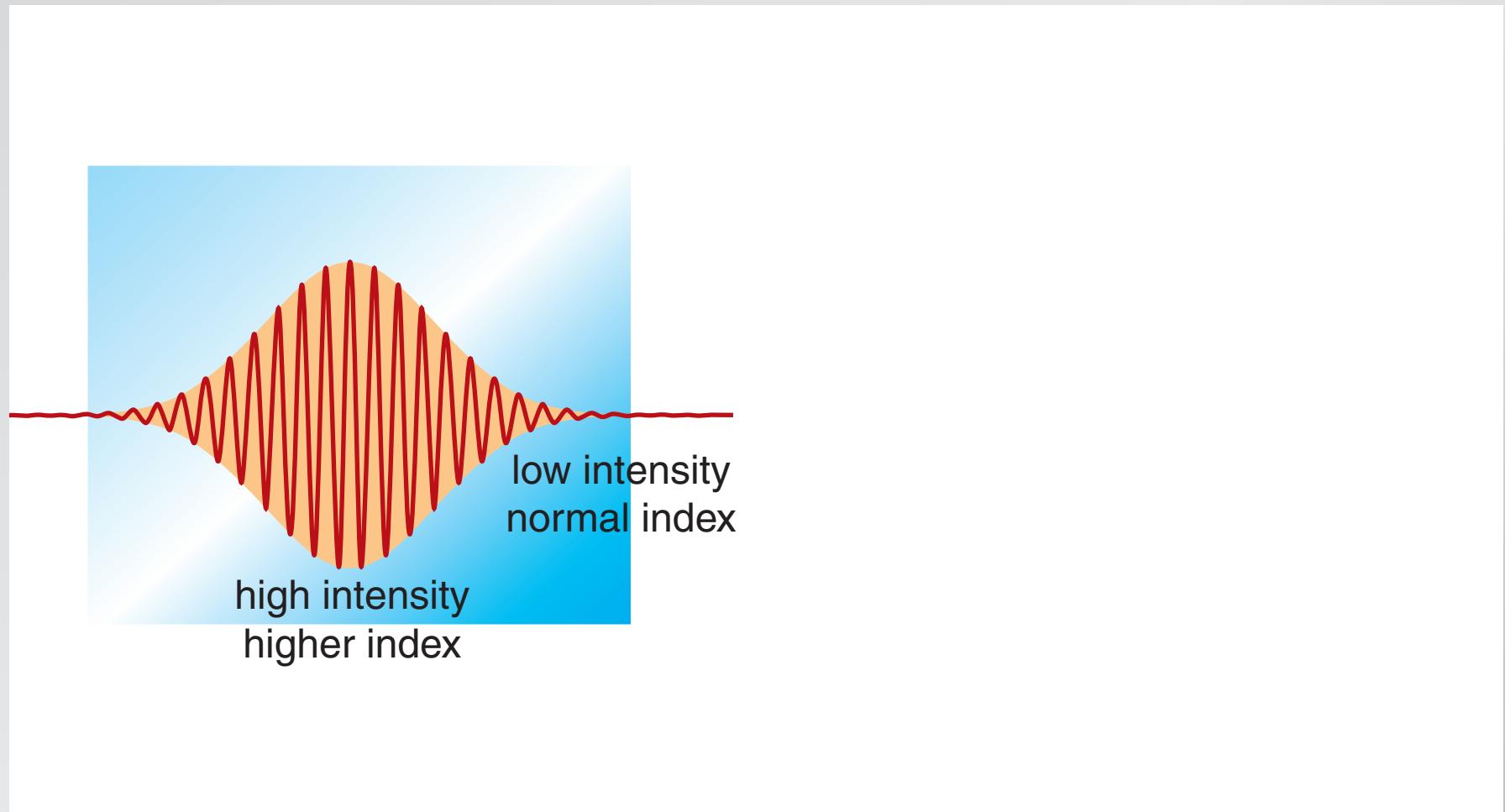
Nanoscale nonlinear optics

nonlinear dispersion: $n = n_0 + n_2 I$



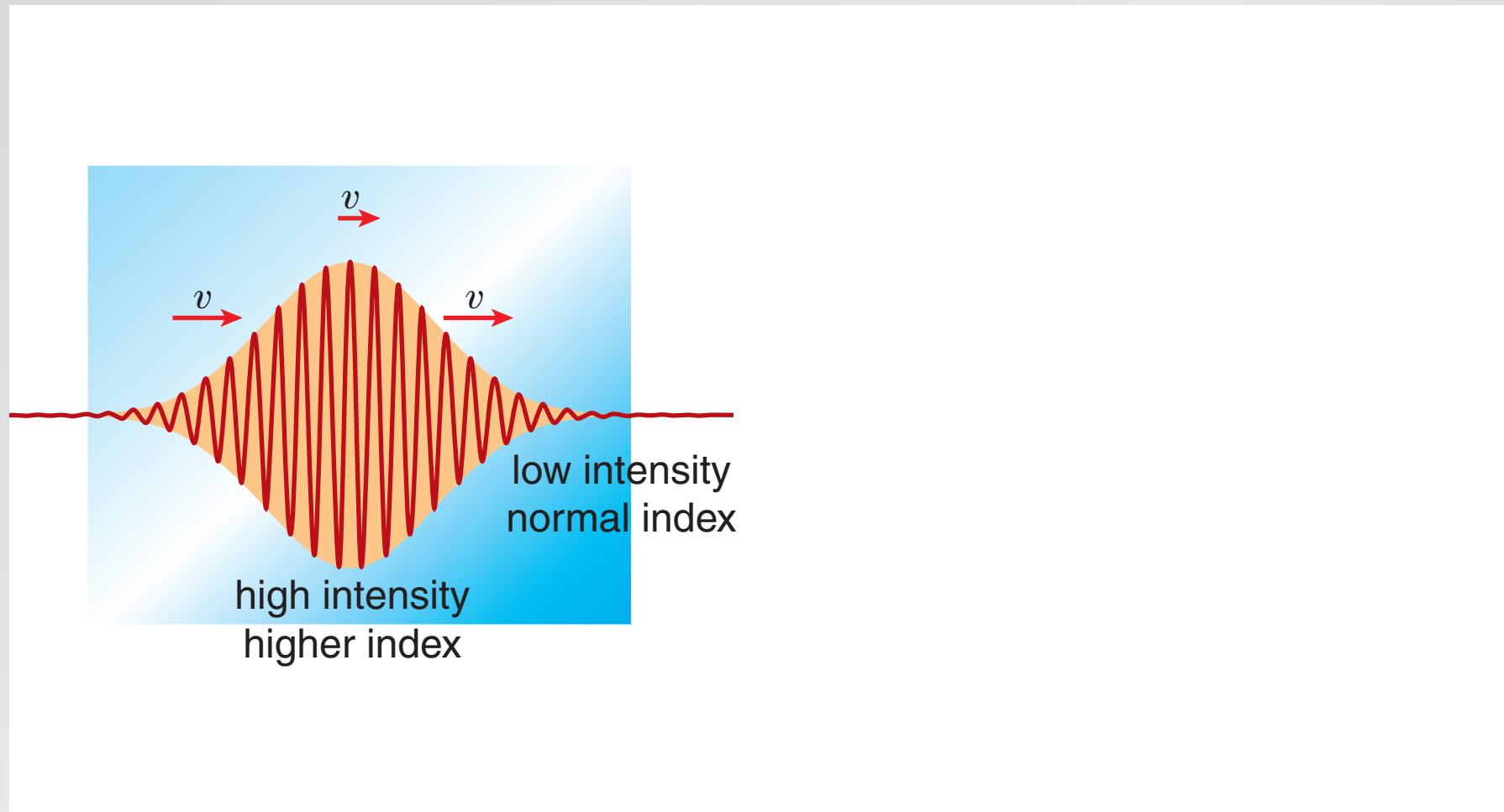
Nanoscale nonlinear optics

nonlinear dispersion: $n = n_0 + n_2 I$



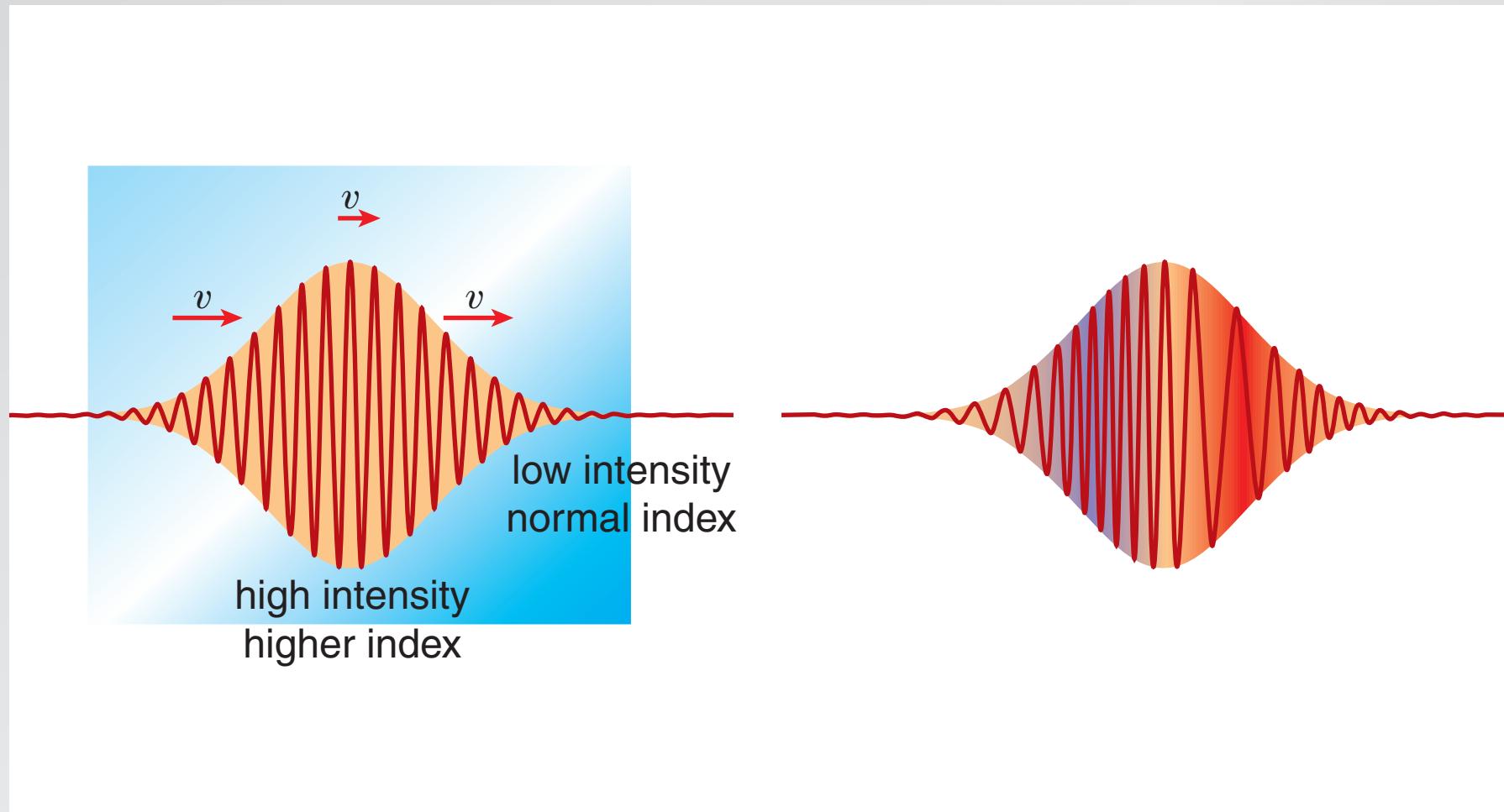
Nanoscale nonlinear optics

nonlinear dispersion: $n = n_0 + n_2 I$



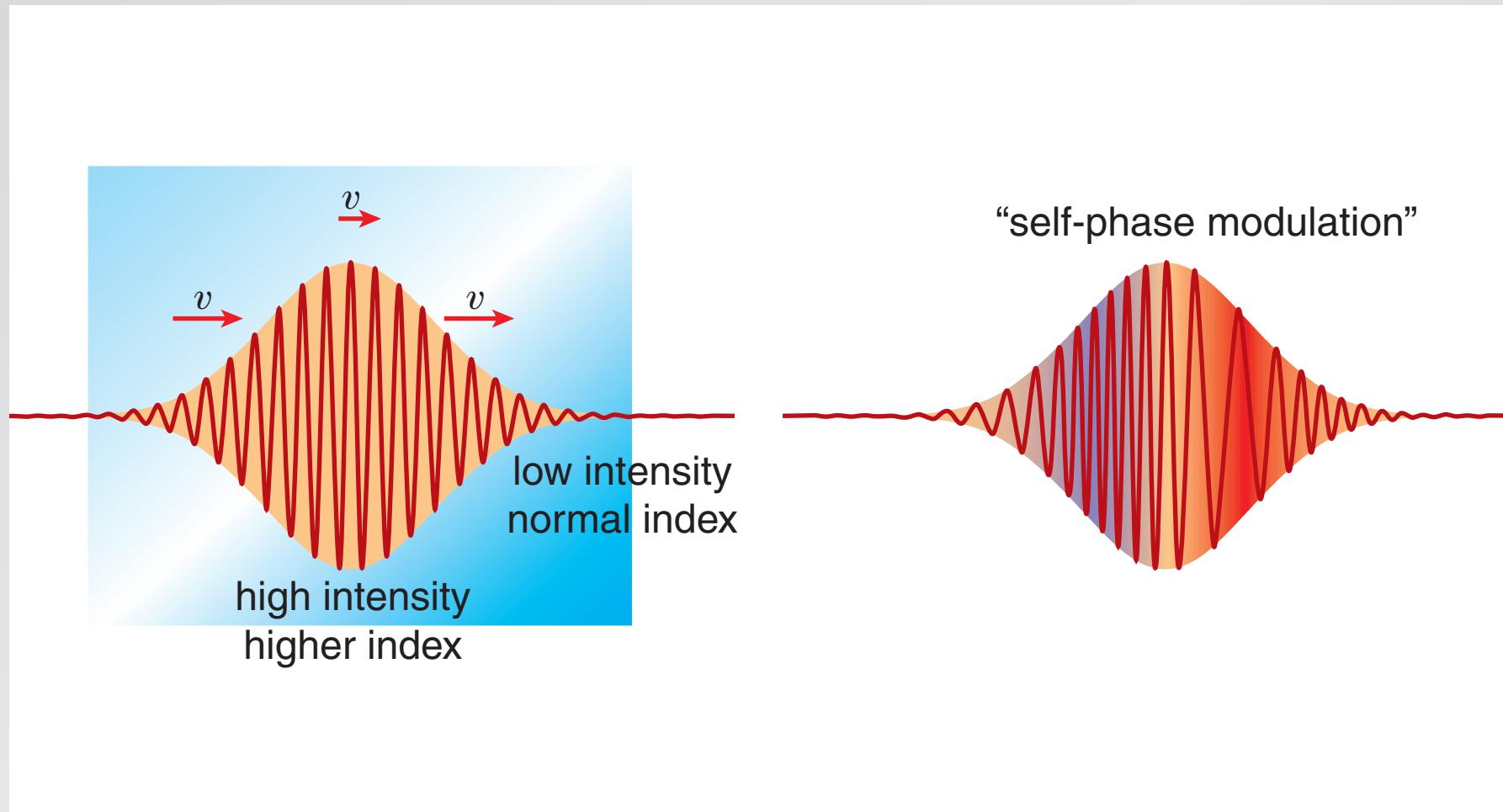
Nanoscale nonlinear optics

nonlinear dispersion: $n = n_0 + n_2 I$

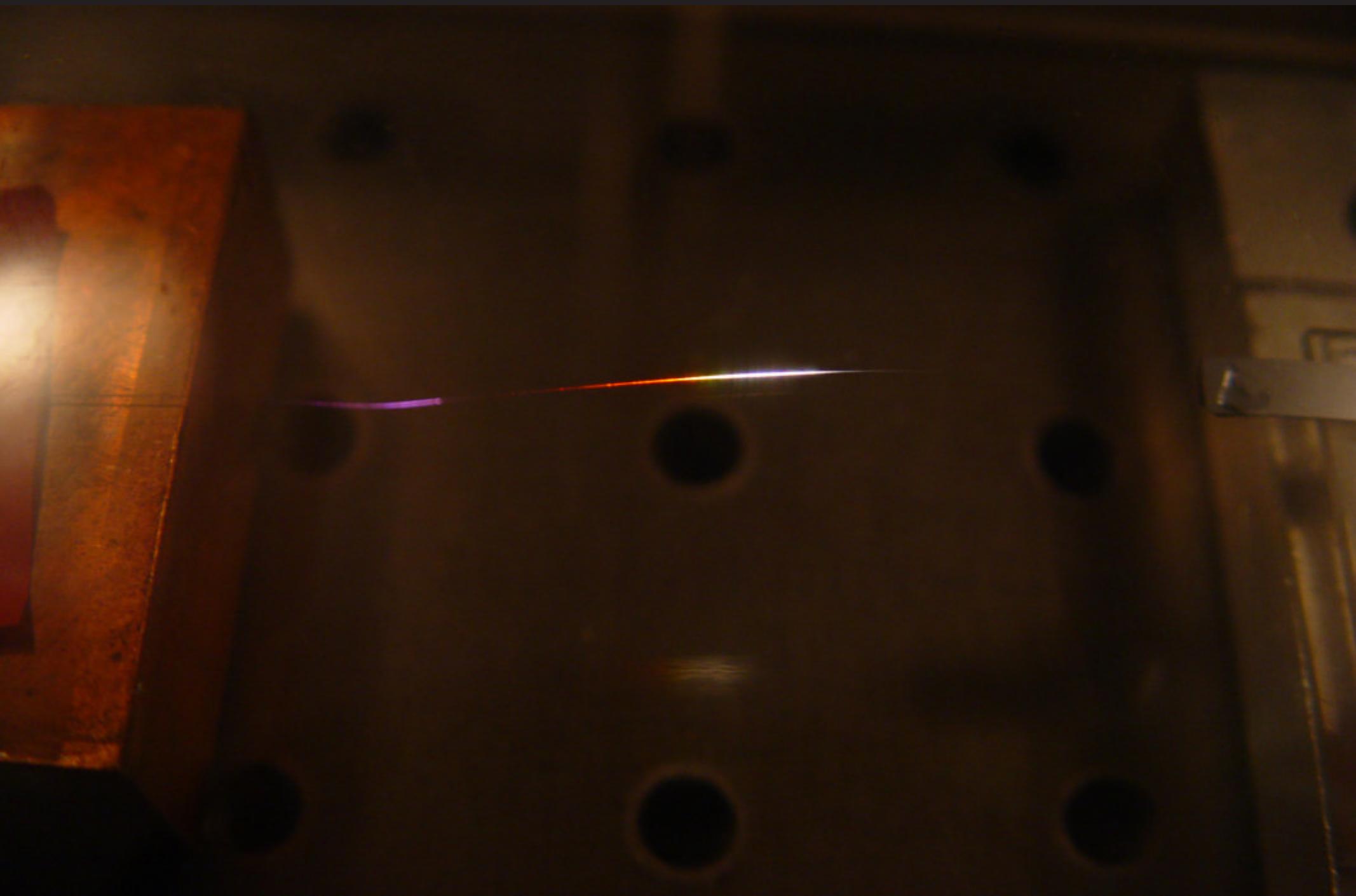


Nanoscale nonlinear optics

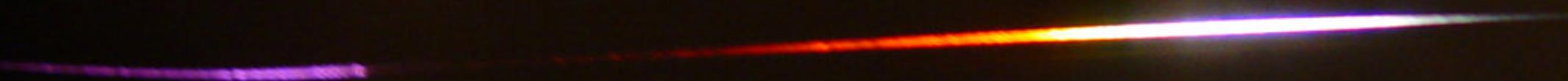
nonlinear dispersion: $n = n_0 + n_2 I$



Nanoscale nonlinear optics



Nanoscale nonlinear optics

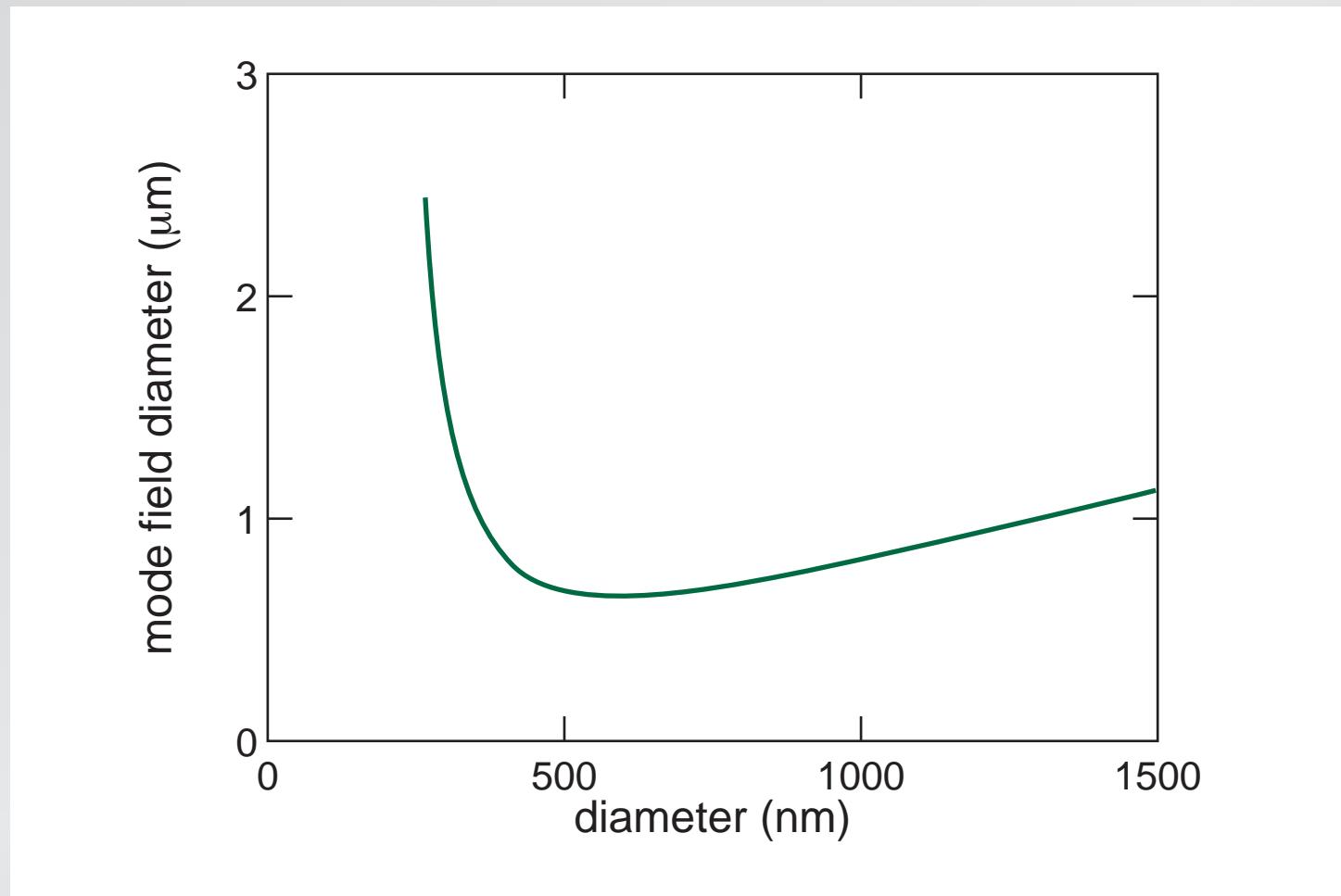


Nanoscale nonlinear optics

strong confinement → **high intensity**

Nanoscale nonlinear optics

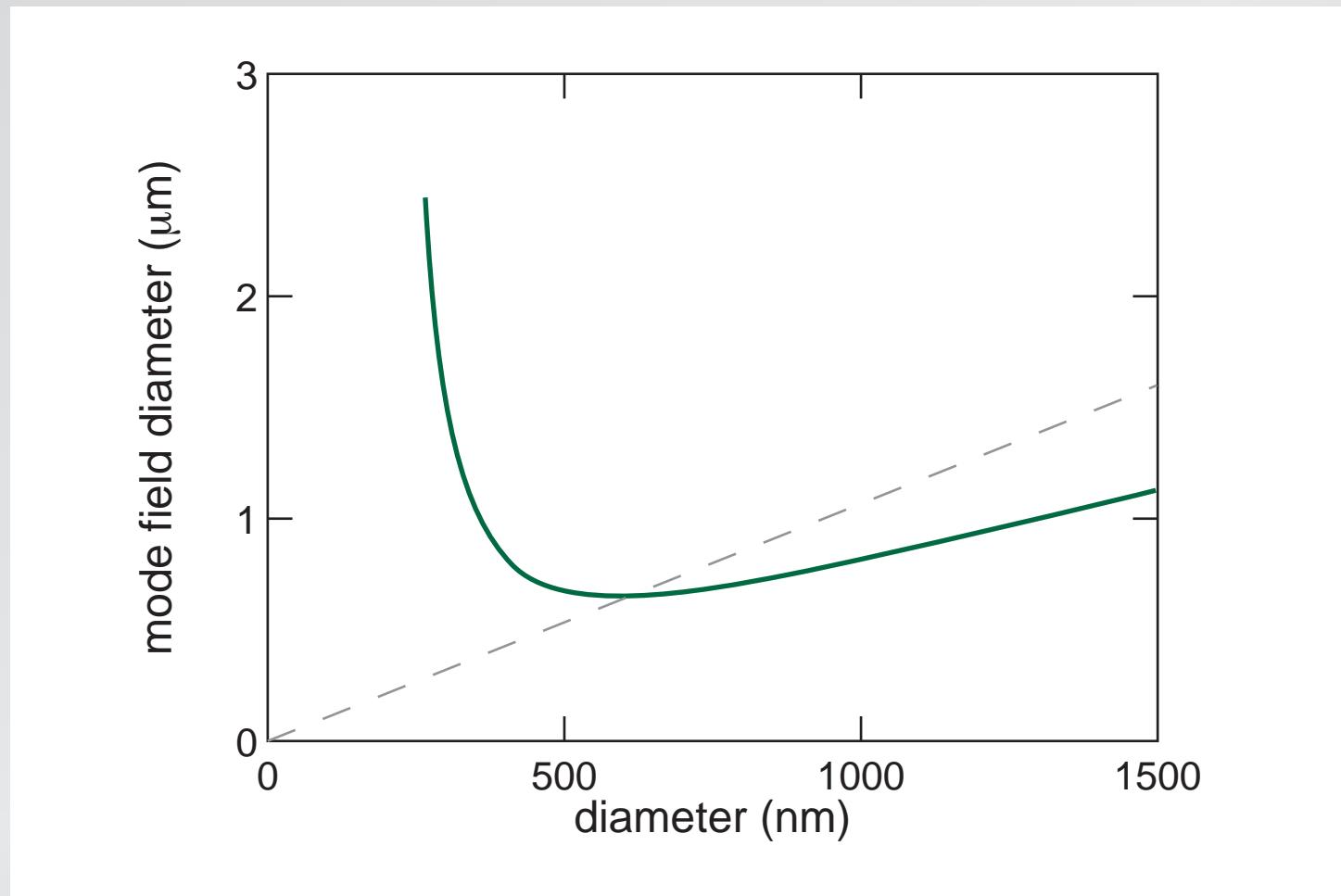
mode field diameter ($\lambda = 800 \text{ nm}$)



M.A. Foster, et al., *Optics Express*, 12, 2880 (2004)

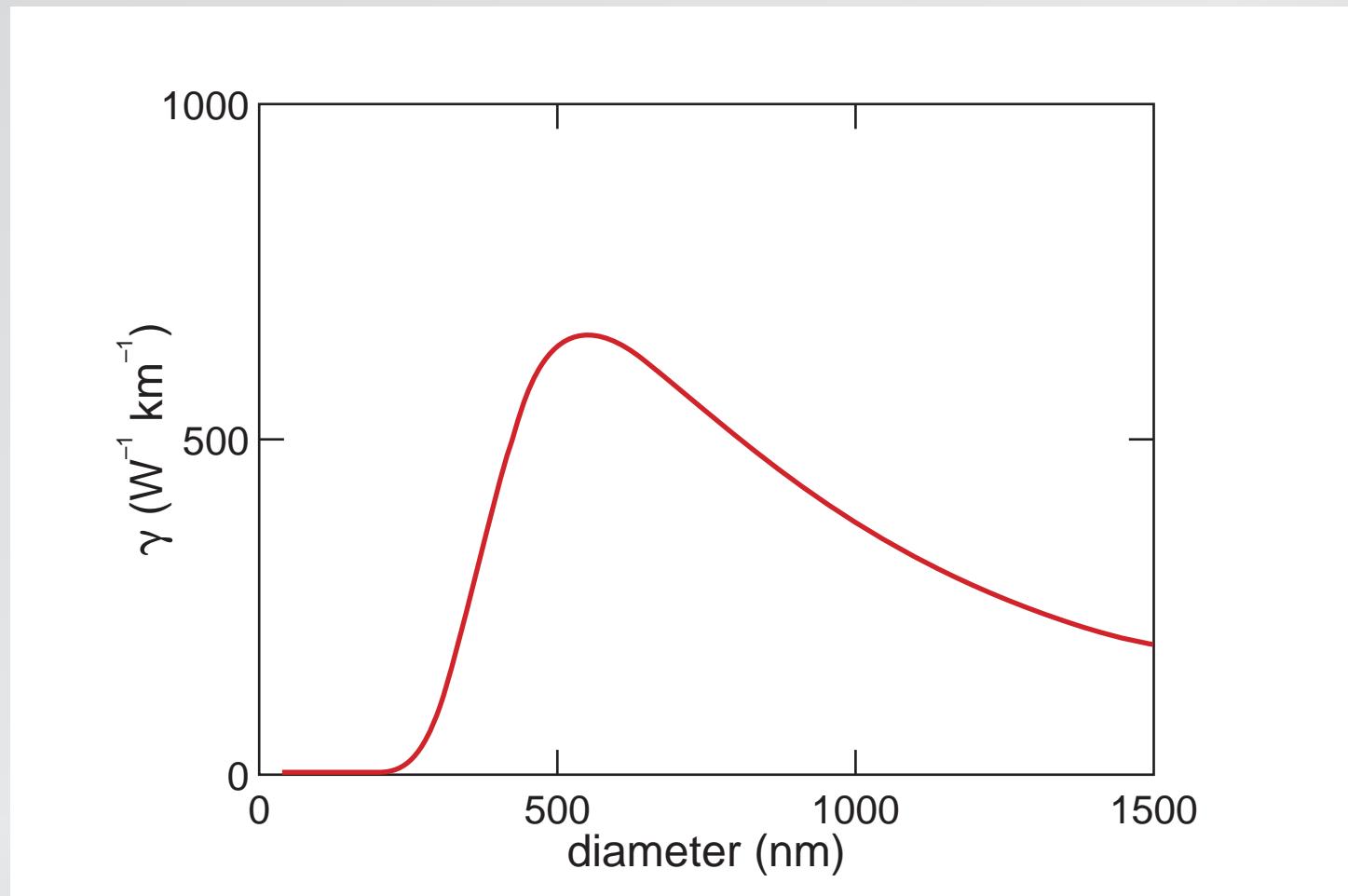
Nanoscale nonlinear optics

mode field diameter ($\lambda = 800 \text{ nm}$)



Nanoscale nonlinear optics

nonlinear parameter



M.A. Foster, et al., *Optics Express*, 12, 2880 (2004)

Nanoscale nonlinear optics

dispersion important!

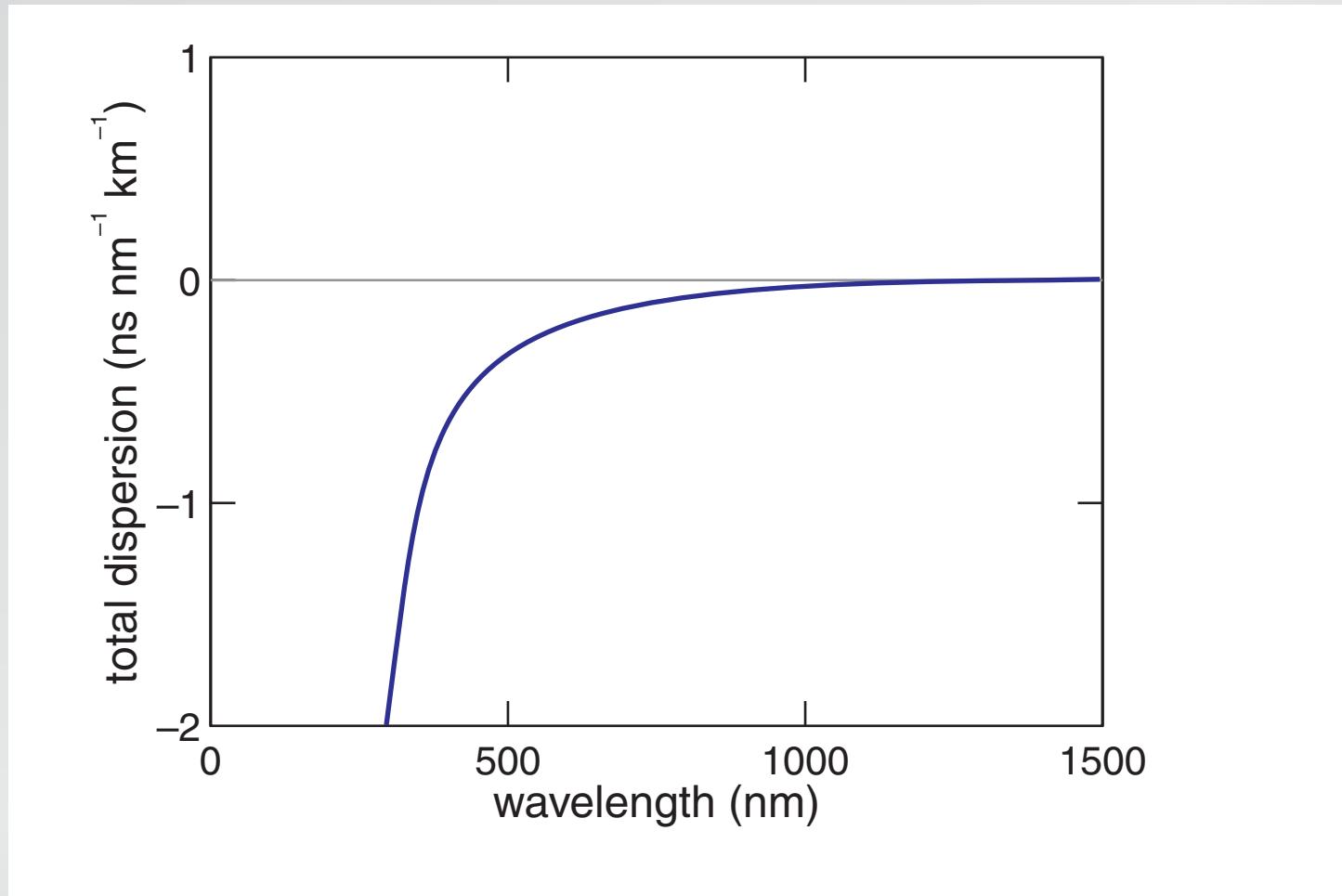
Nanoscale nonlinear optics

dispersion:

- modal dispersion
- material dispersion
- waveguide dispersion
- nonlinear dispersion

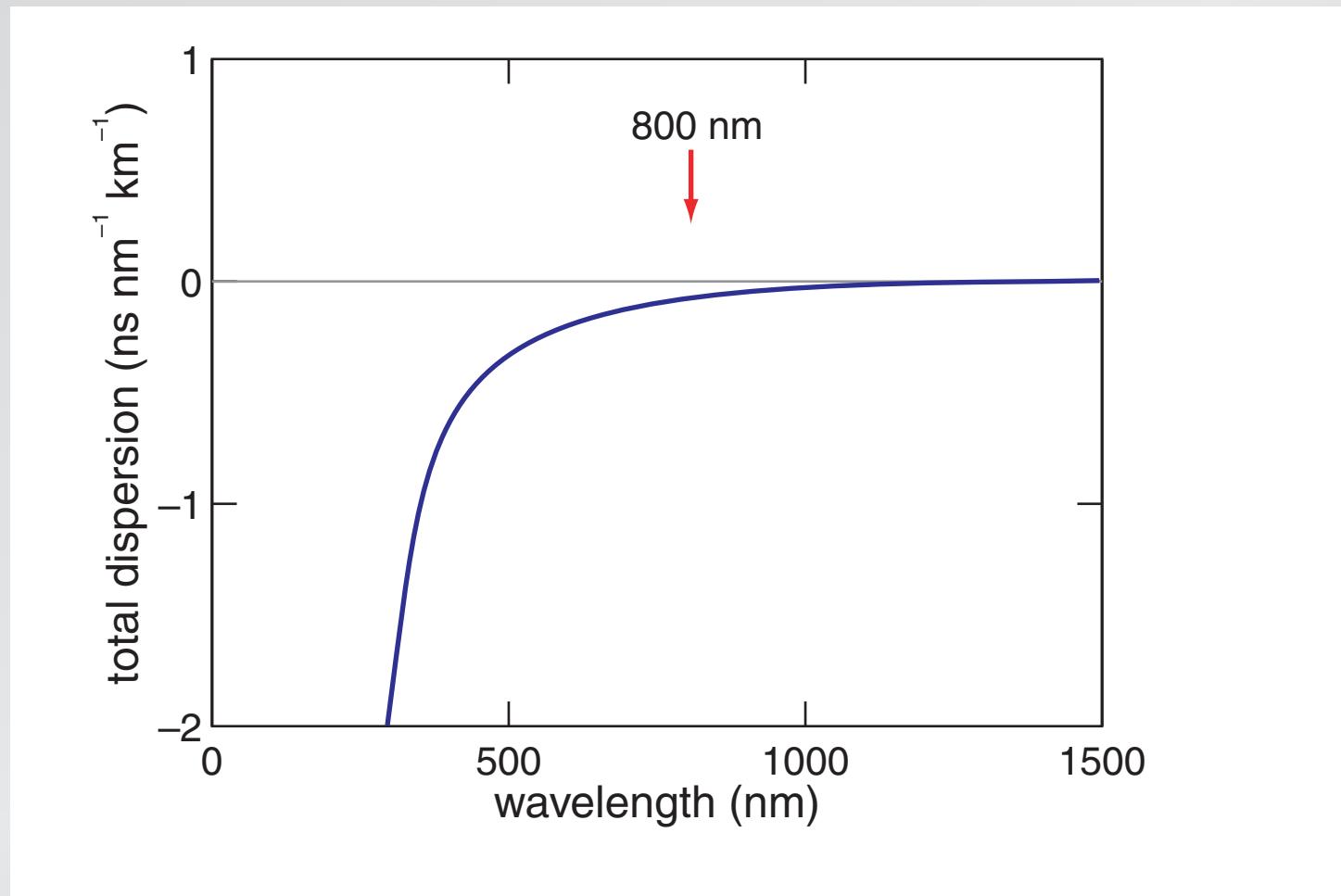
Nanoscale nonlinear optics

waveguide dispersion



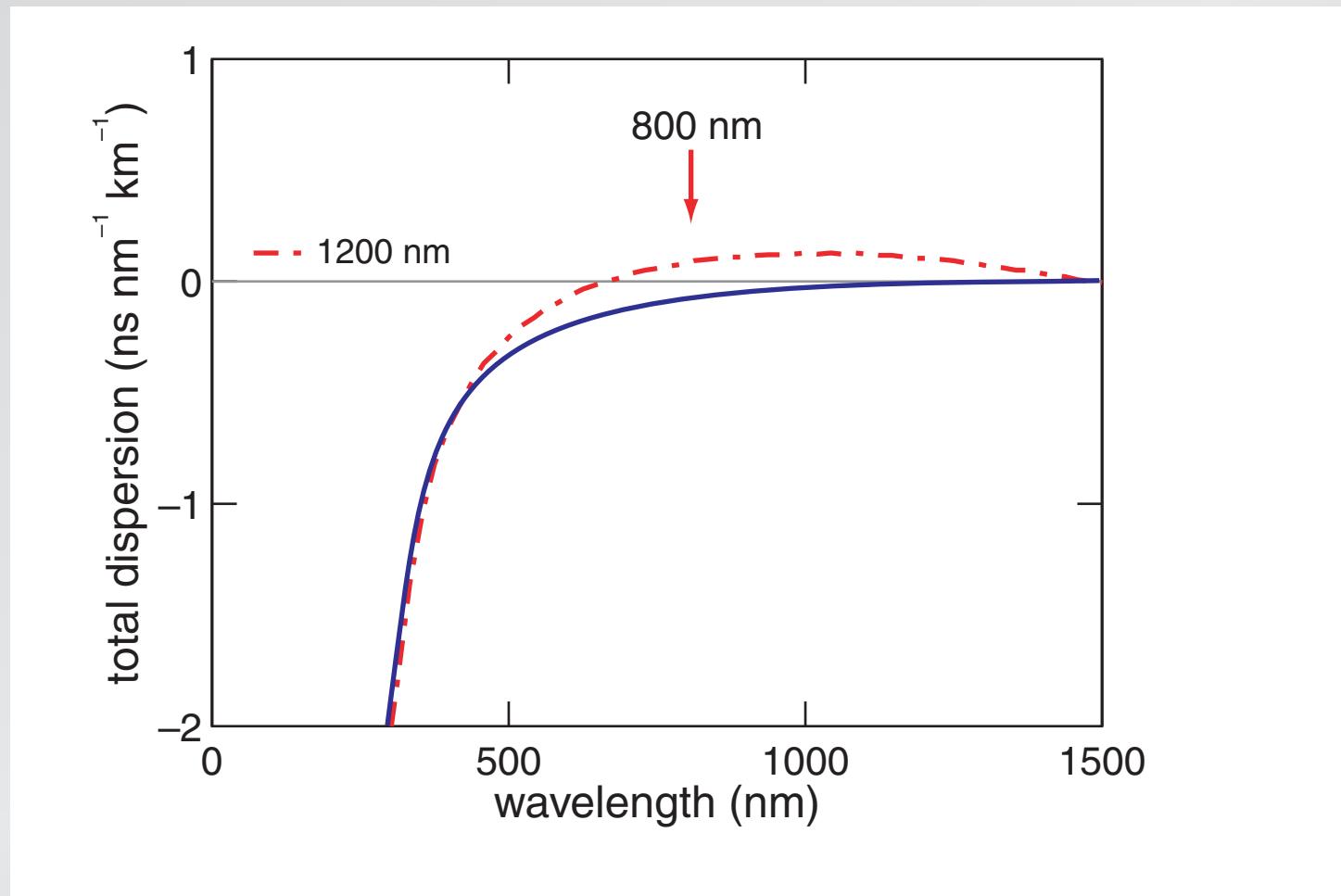
Nanoscale nonlinear optics

waveguide dispersion



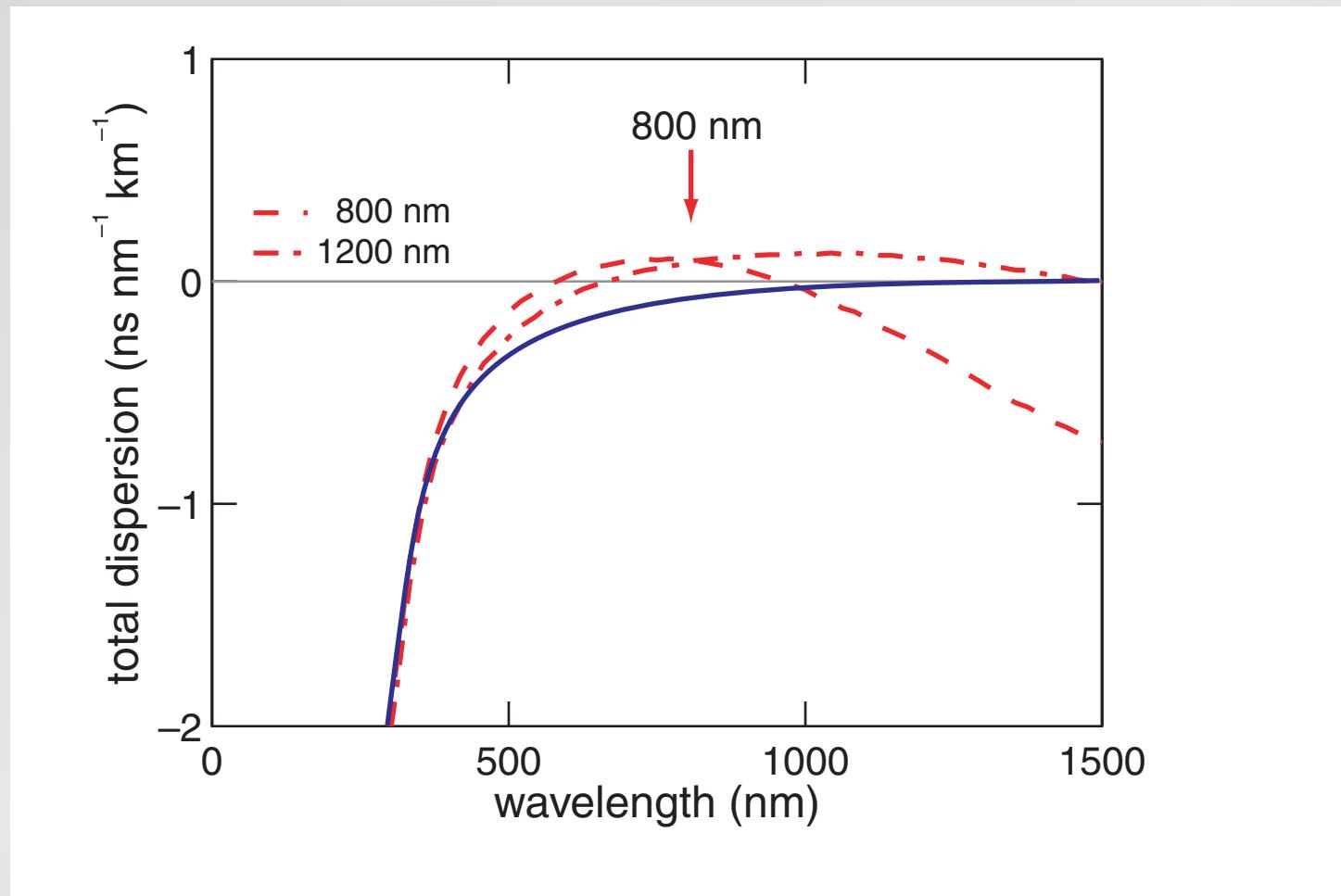
Nanoscale nonlinear optics

waveguide dispersion



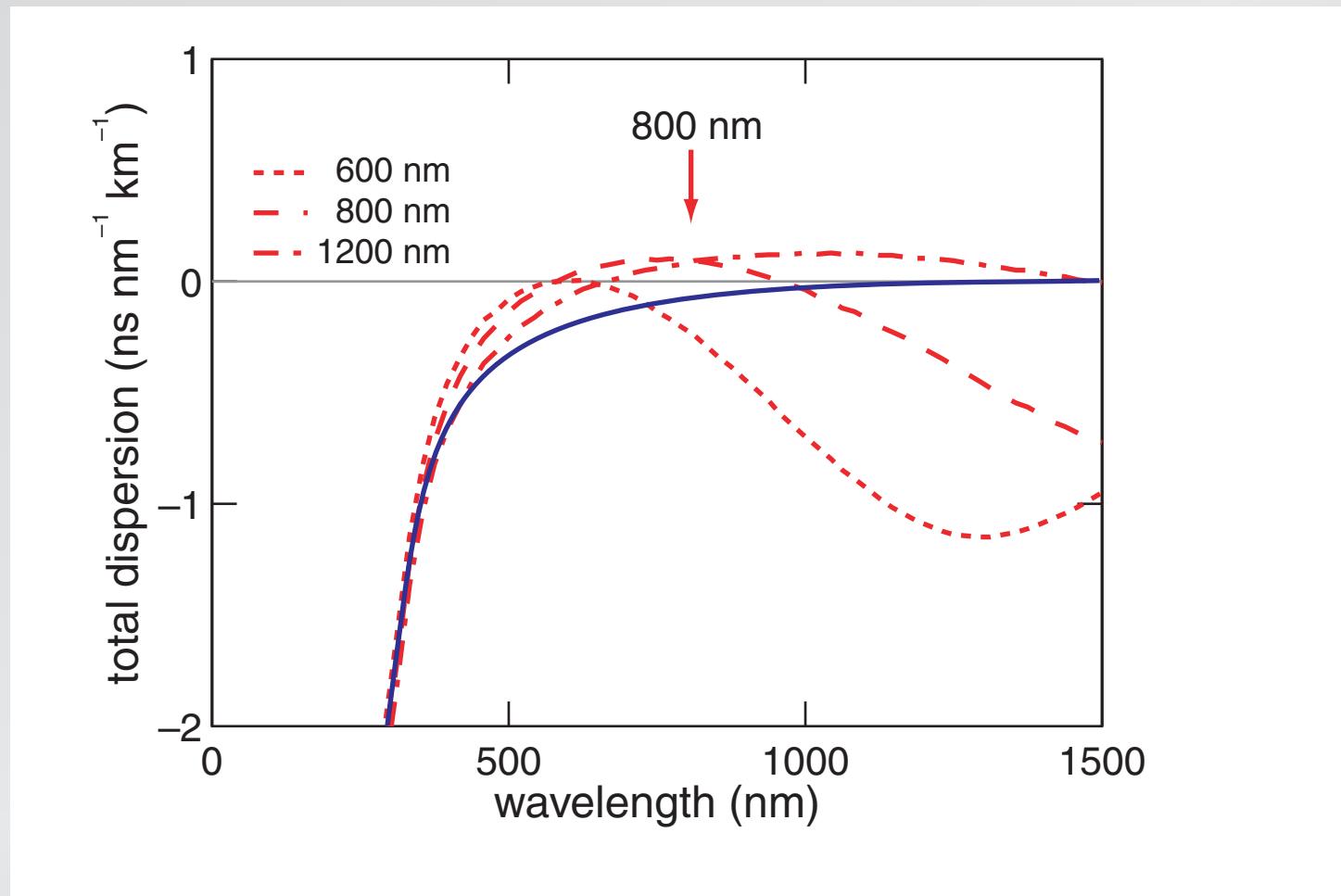
Nanoscale nonlinear optics

waveguide dispersion



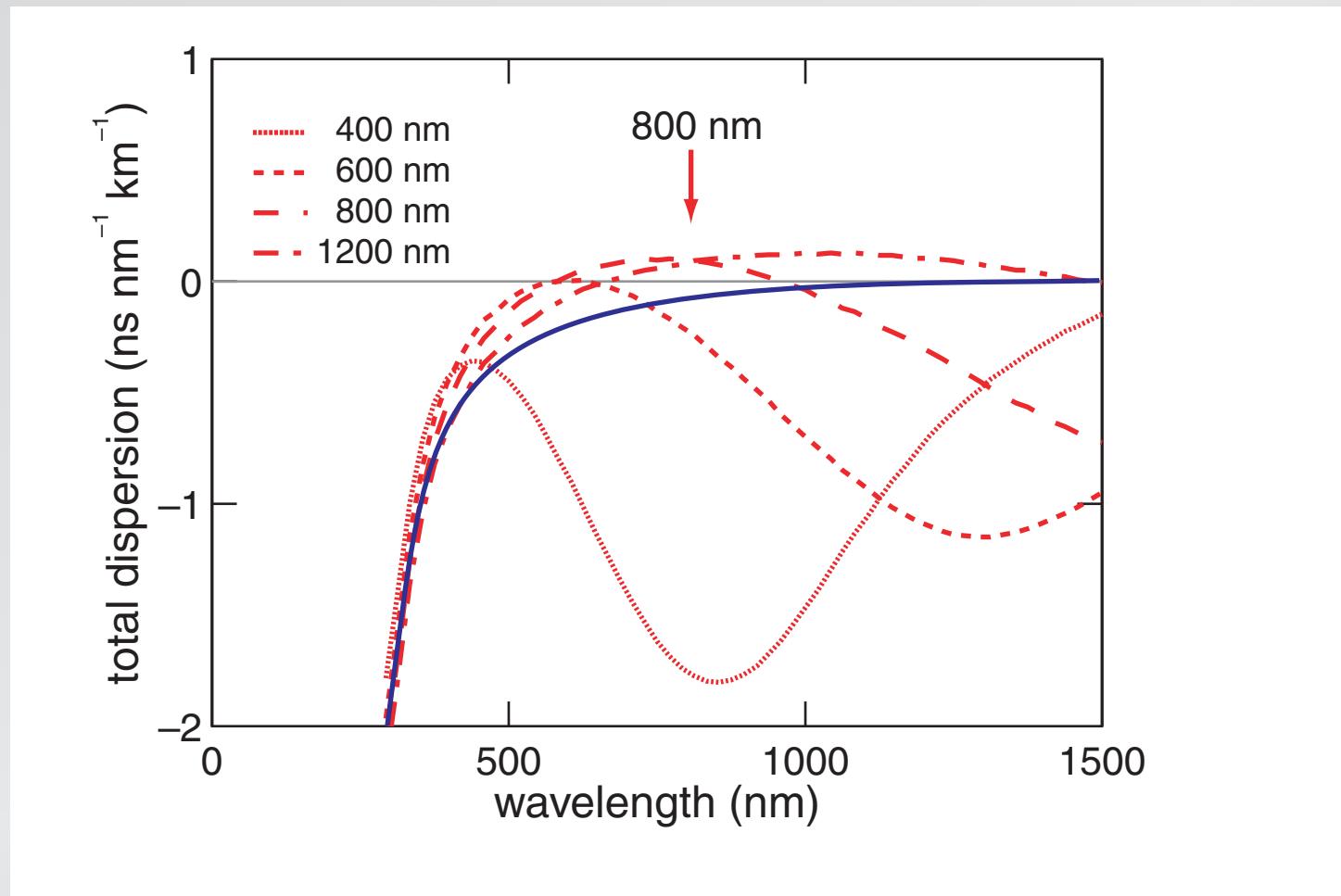
Nanoscale nonlinear optics

waveguide dispersion



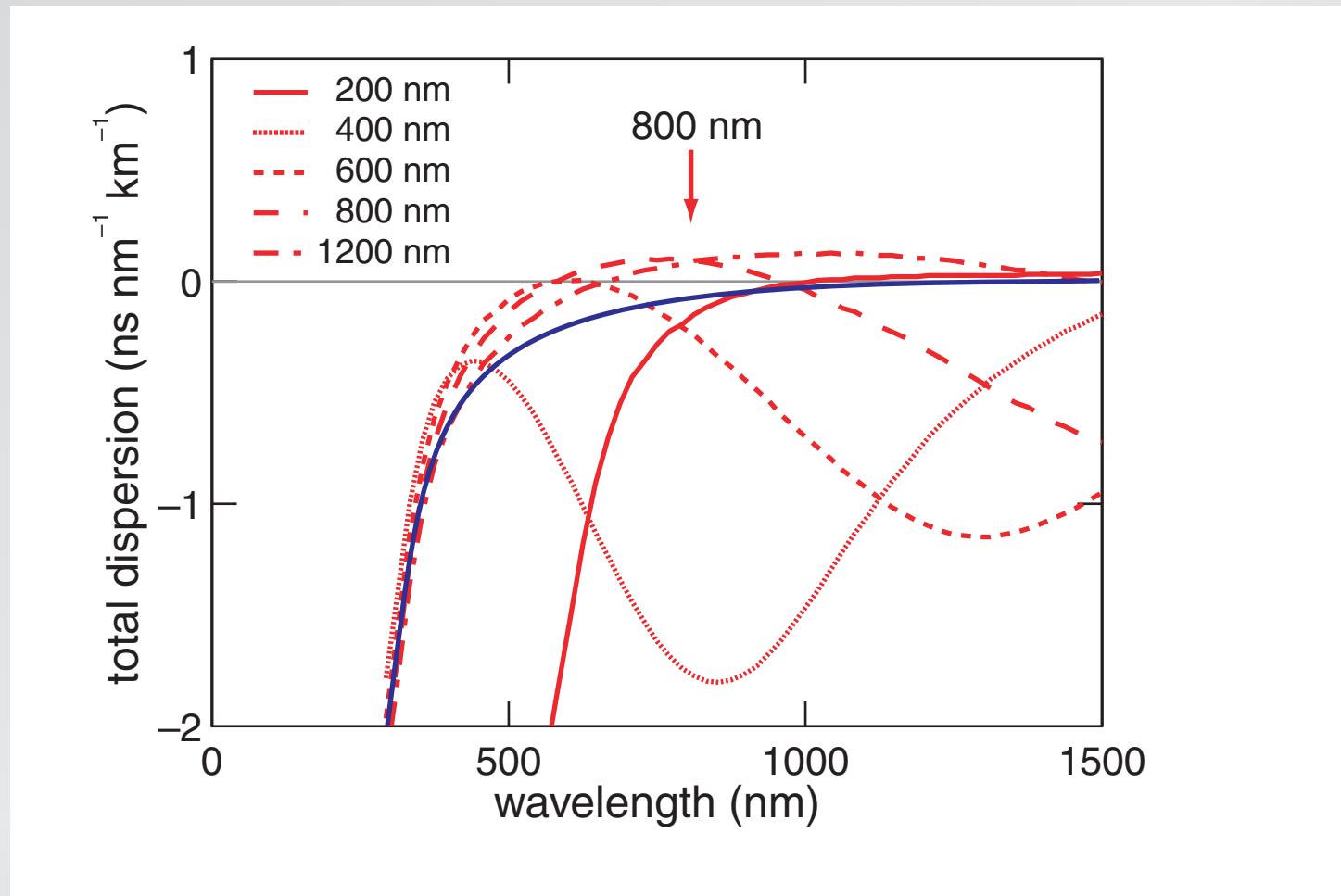
Nanoscale nonlinear optics

waveguide dispersion



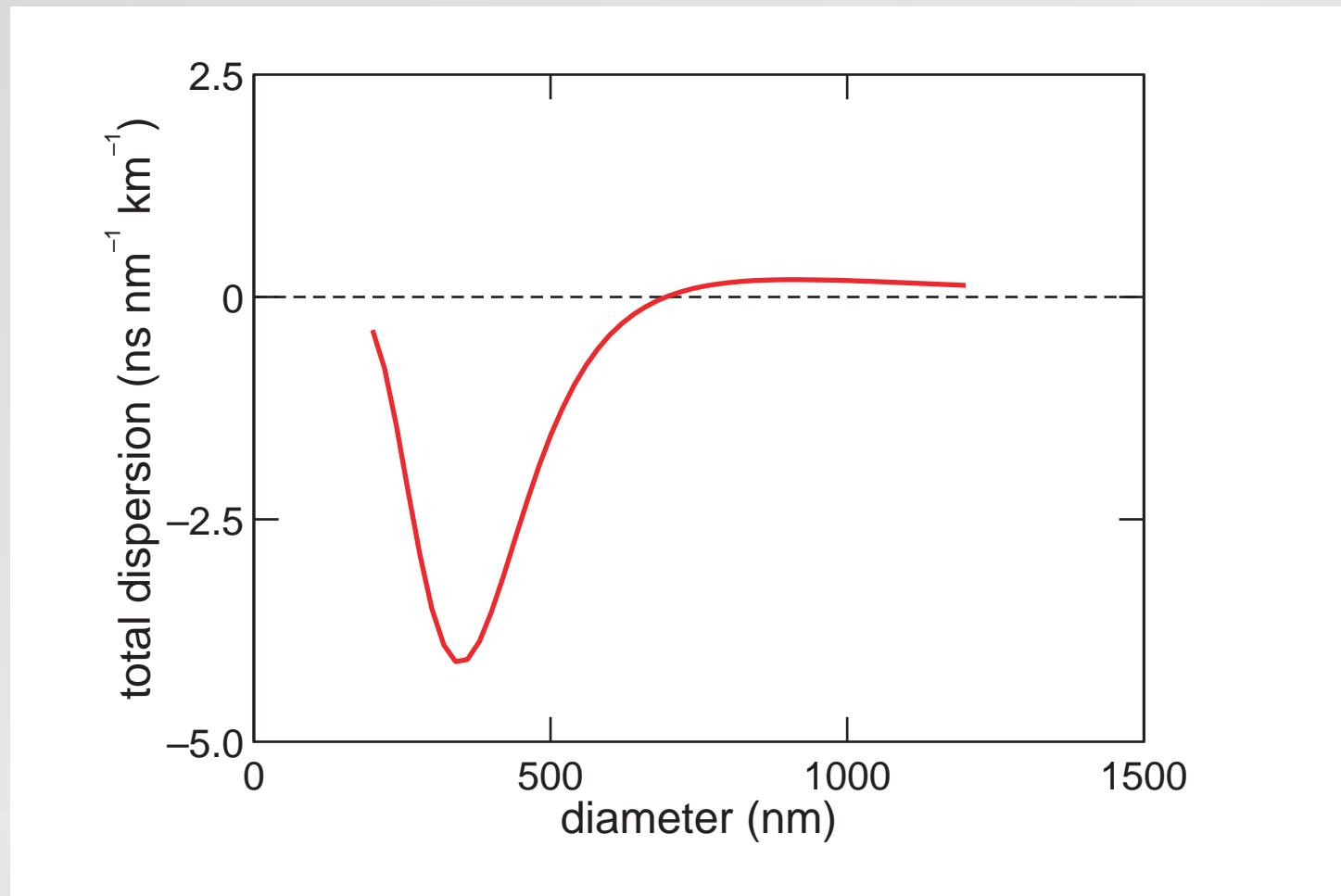
Nanoscale nonlinear optics

waveguide dispersion



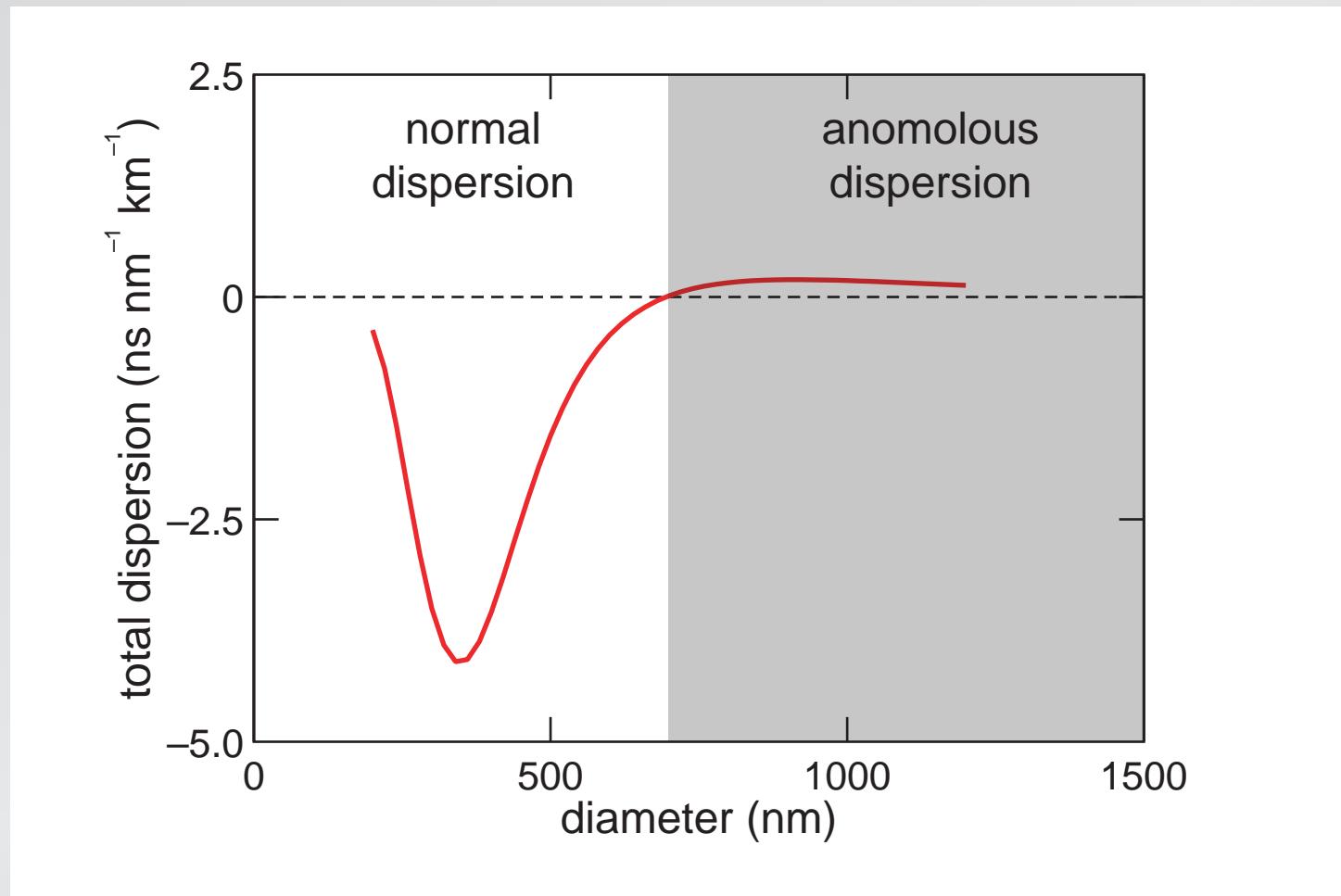
Nanoscale nonlinear optics

waveguide dispersion



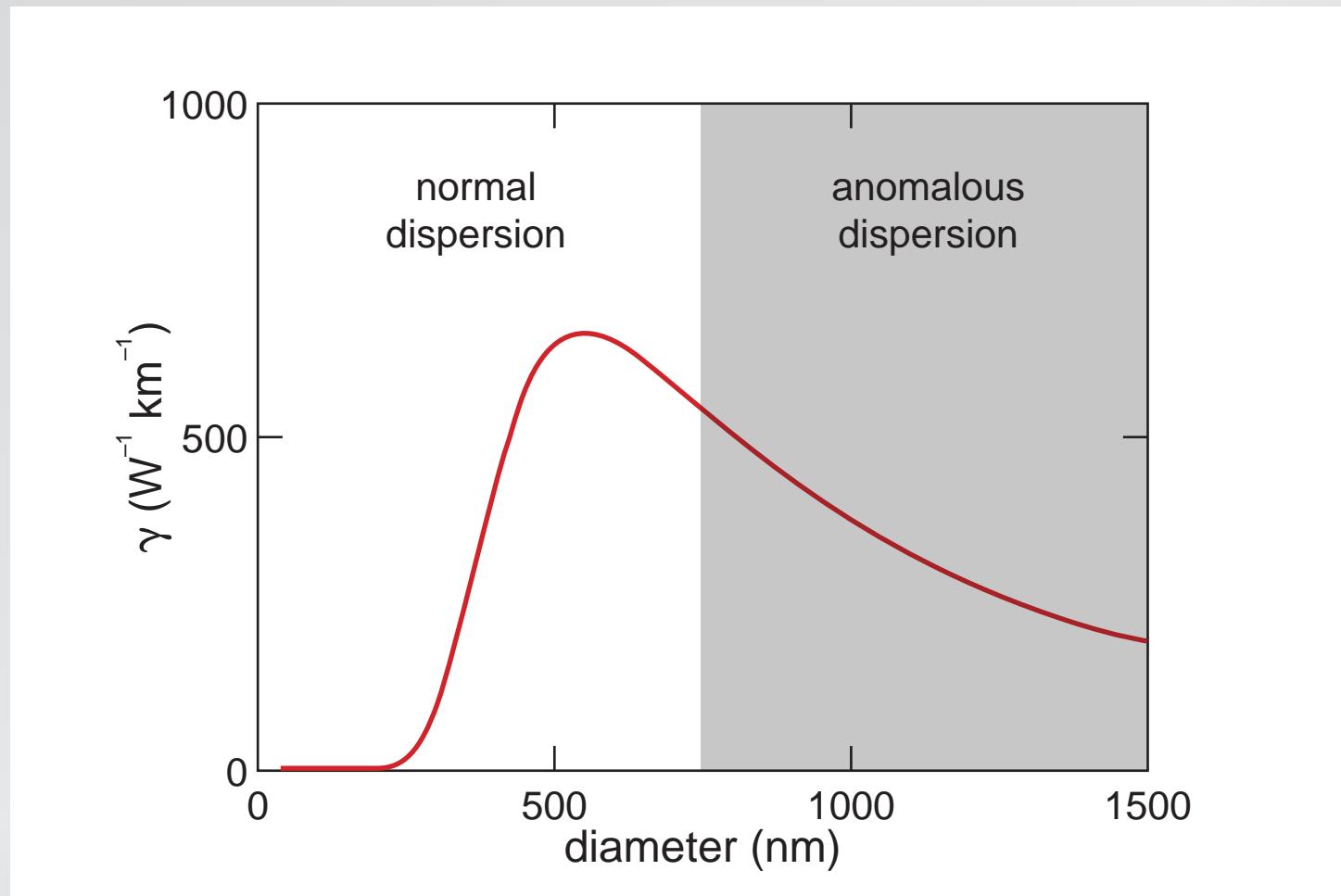
Nanoscale nonlinear optics

waveguide dispersion



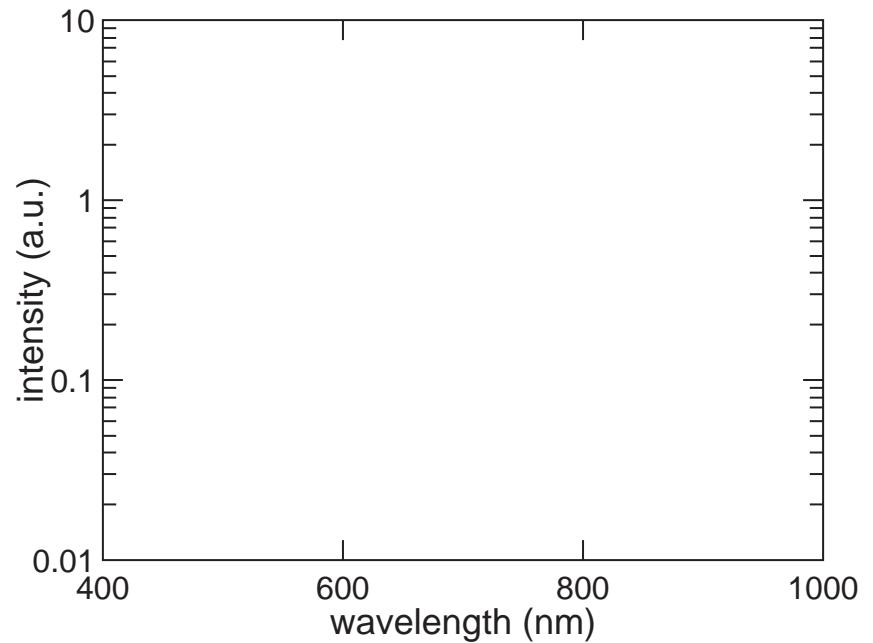
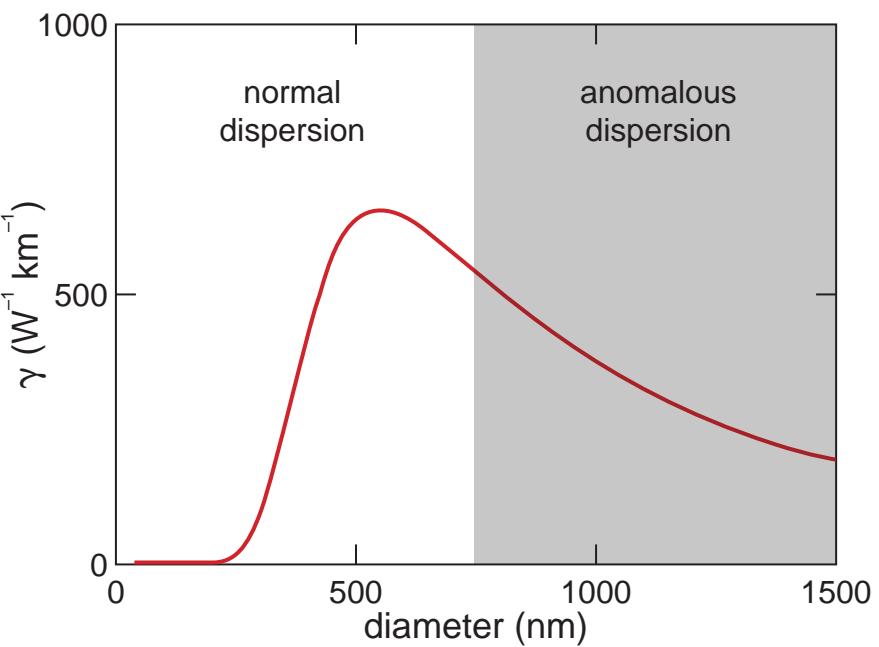
Nanoscale nonlinear optics

nonlinear parameter



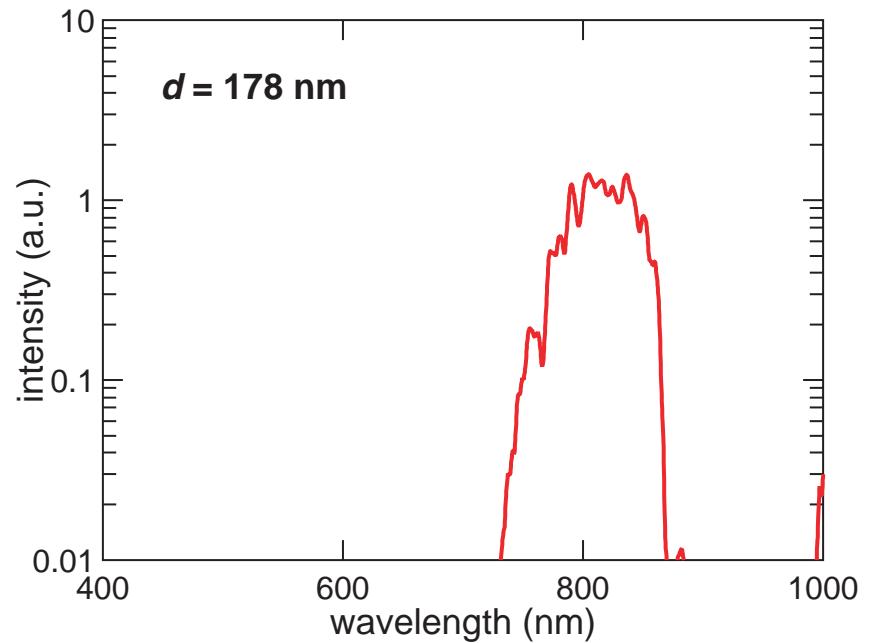
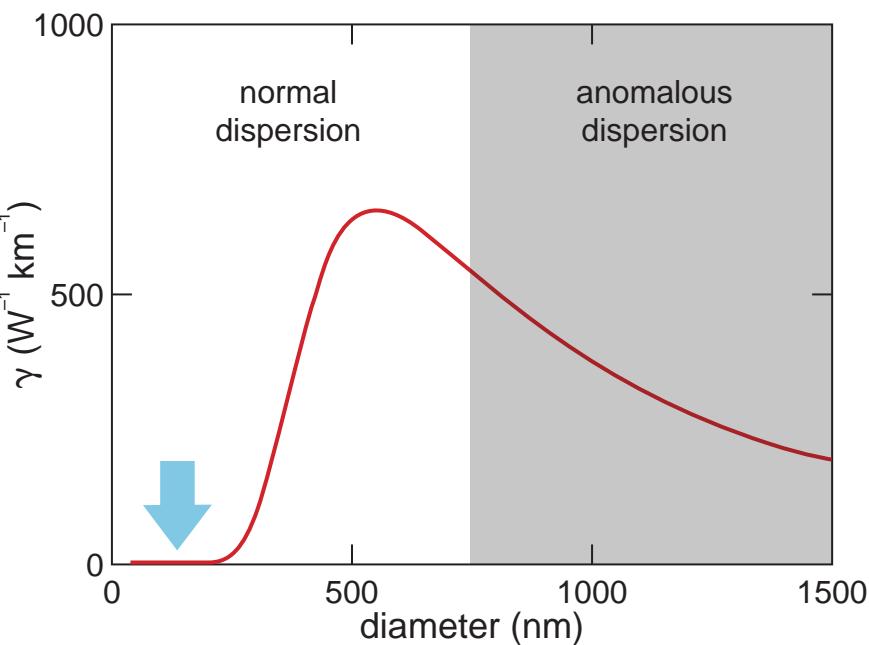
Nanoscale nonlinear optics

nanowire continuum generation



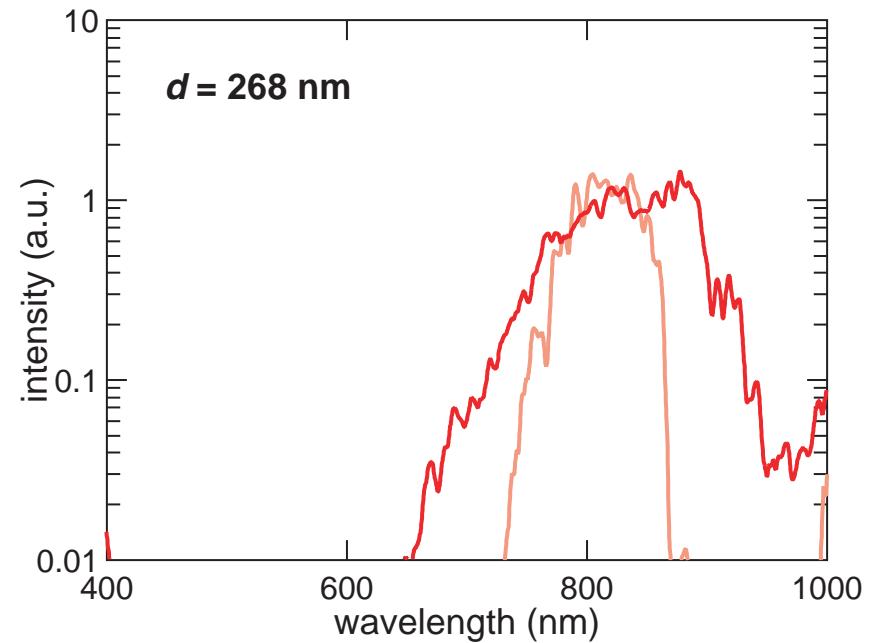
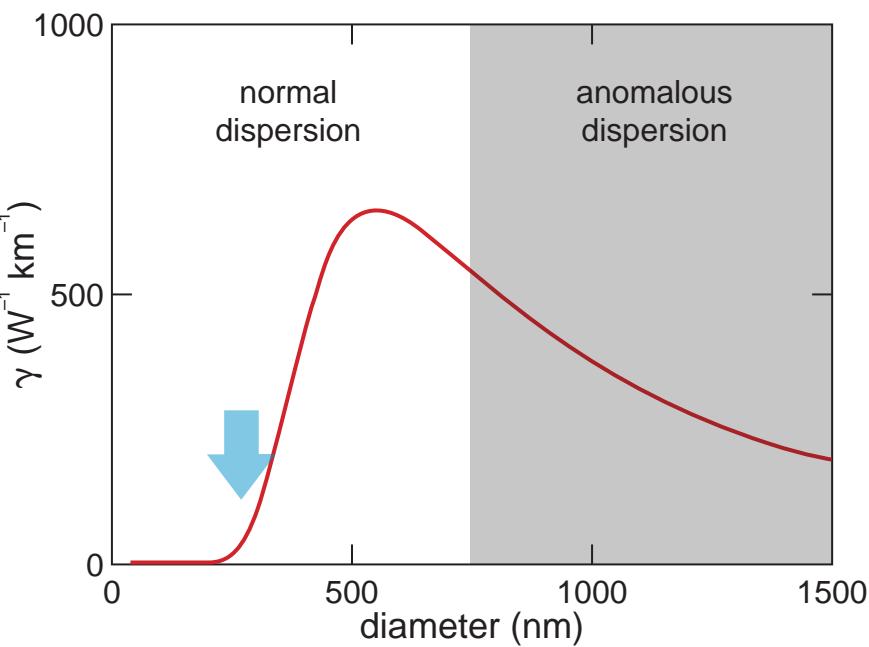
Nanoscale nonlinear optics

nanowire continuum generation



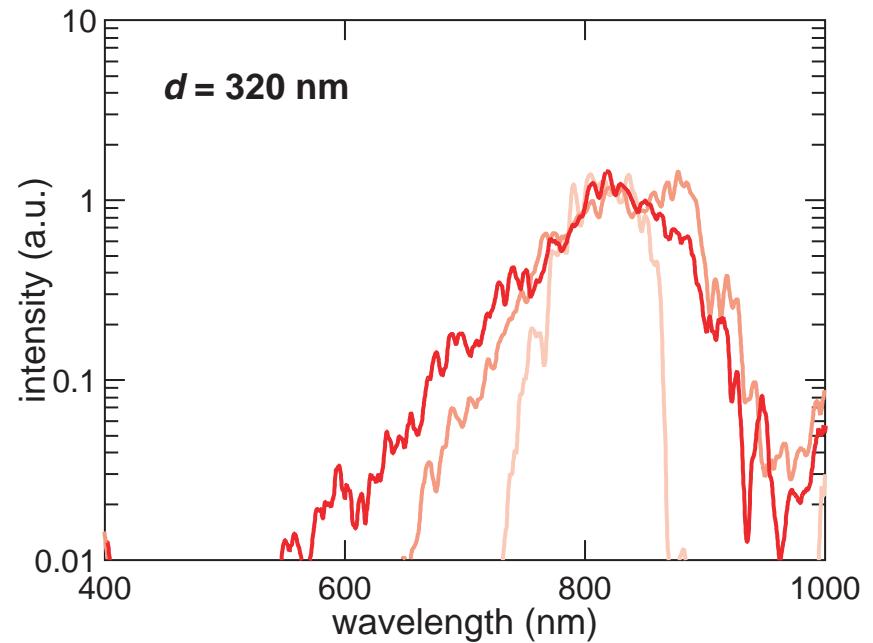
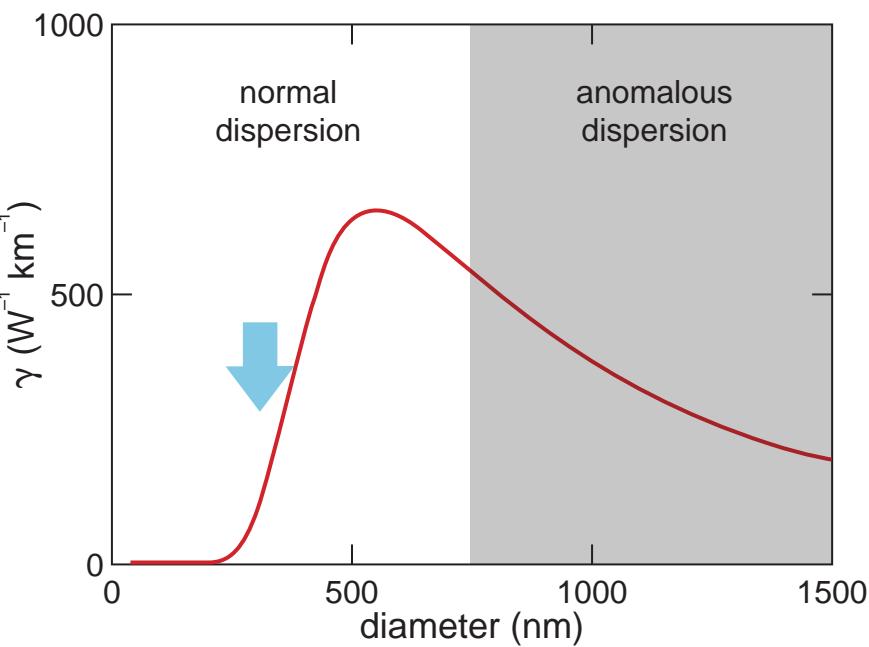
Nanoscale nonlinear optics

nanowire continuum generation



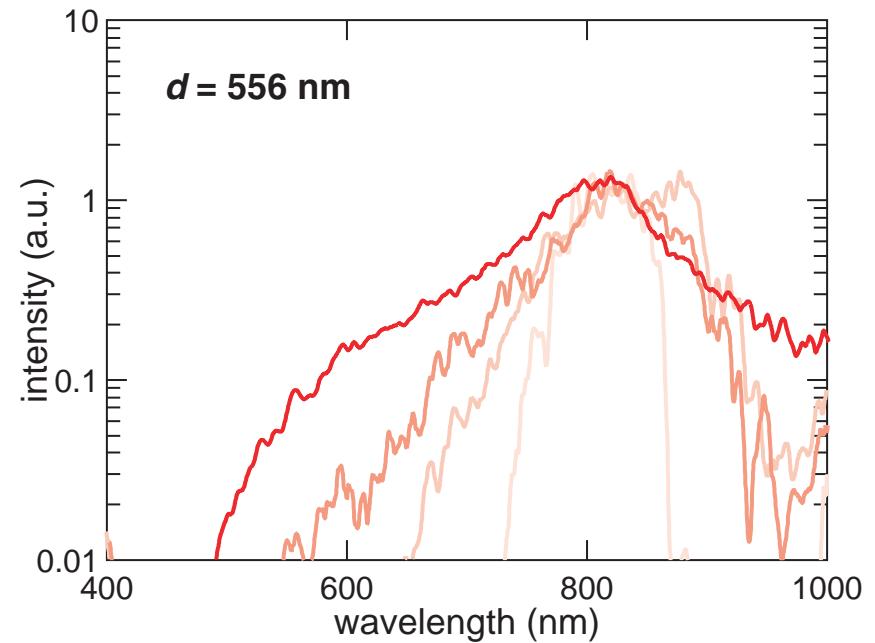
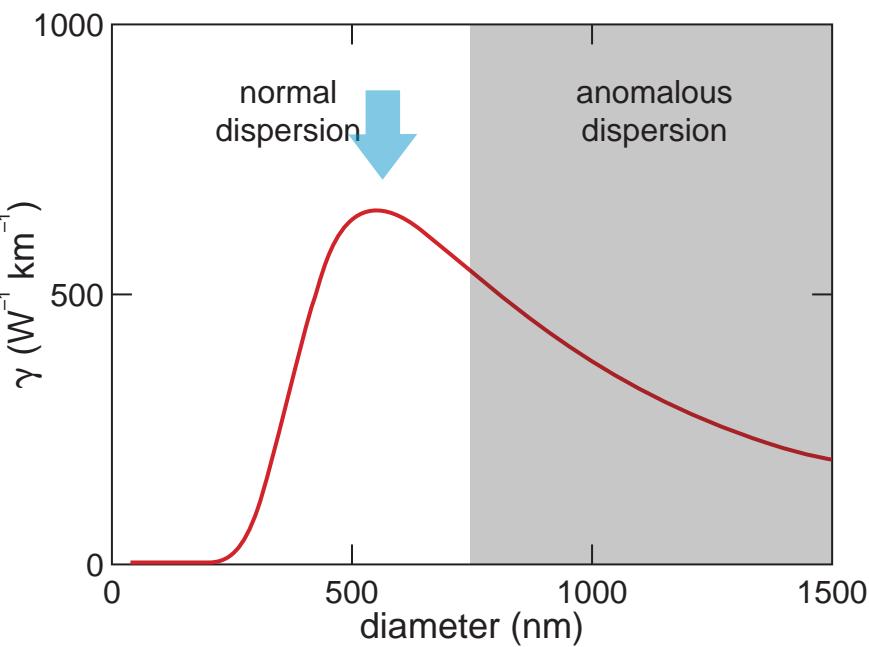
Nanoscale nonlinear optics

nanowire continuum generation



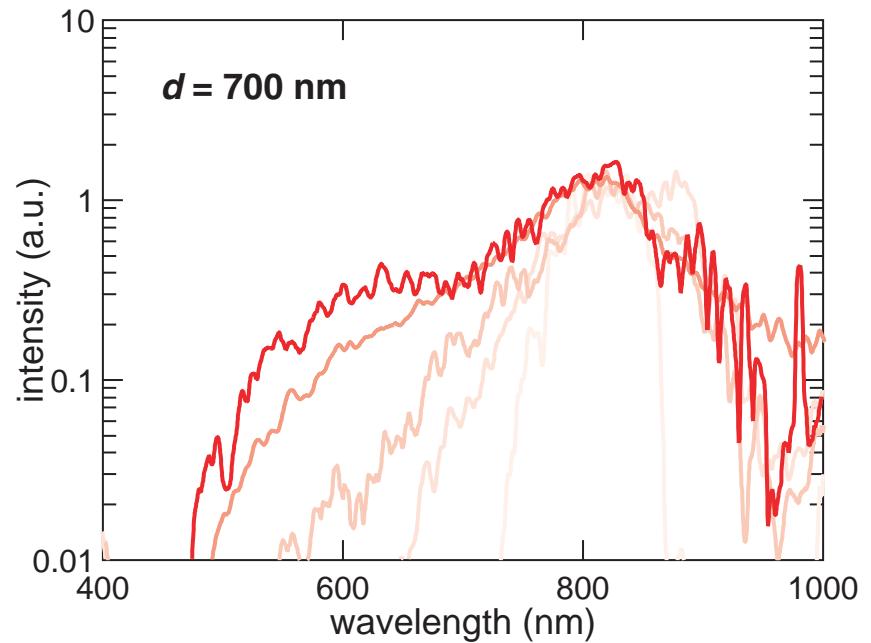
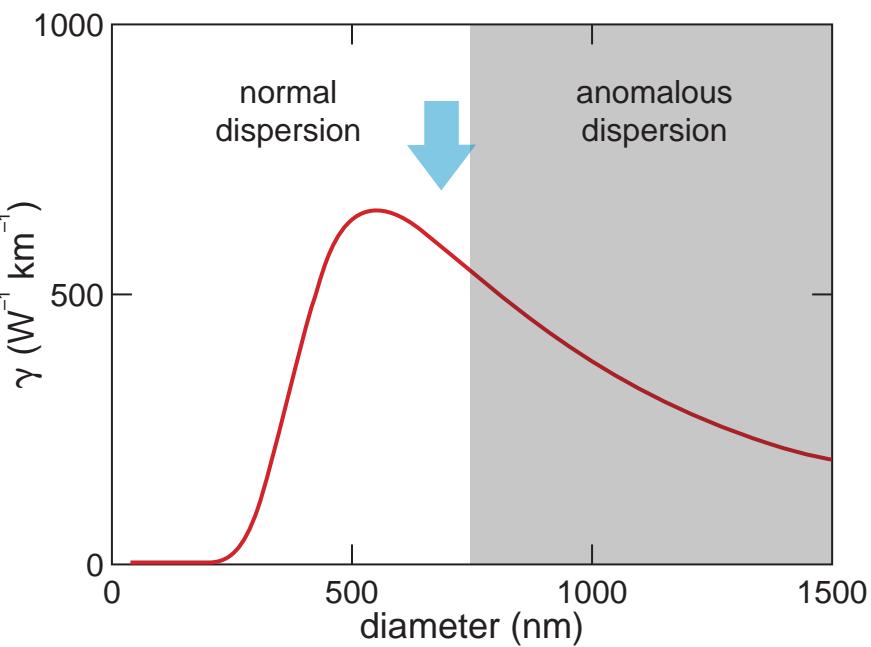
Nanoscale nonlinear optics

nanowire continuum generation



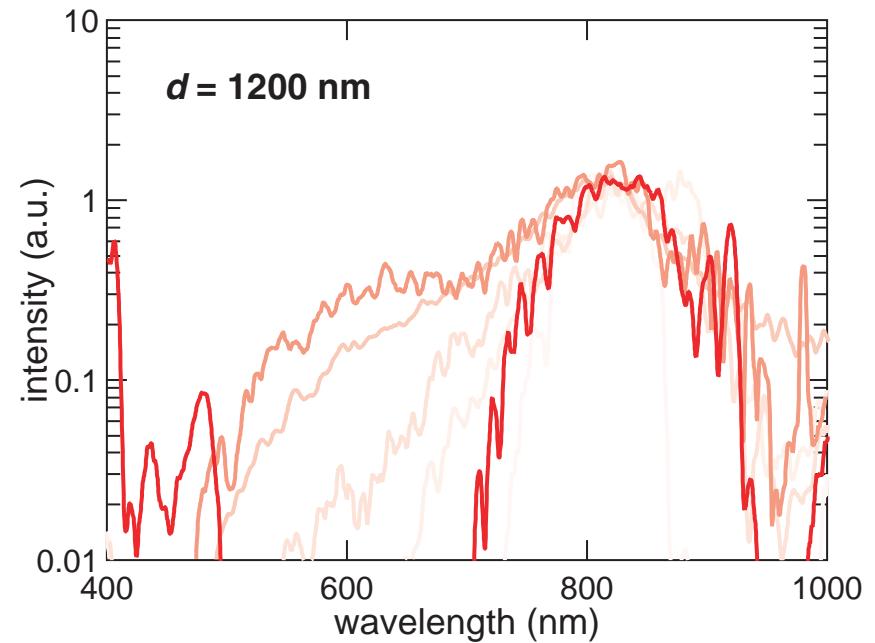
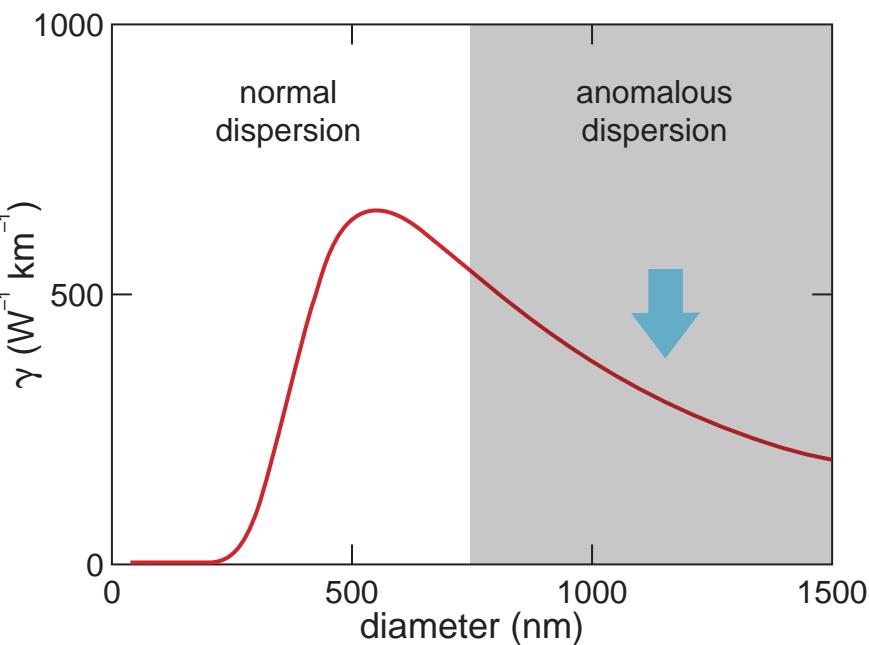
Nanoscale nonlinear optics

nanowire continuum generation



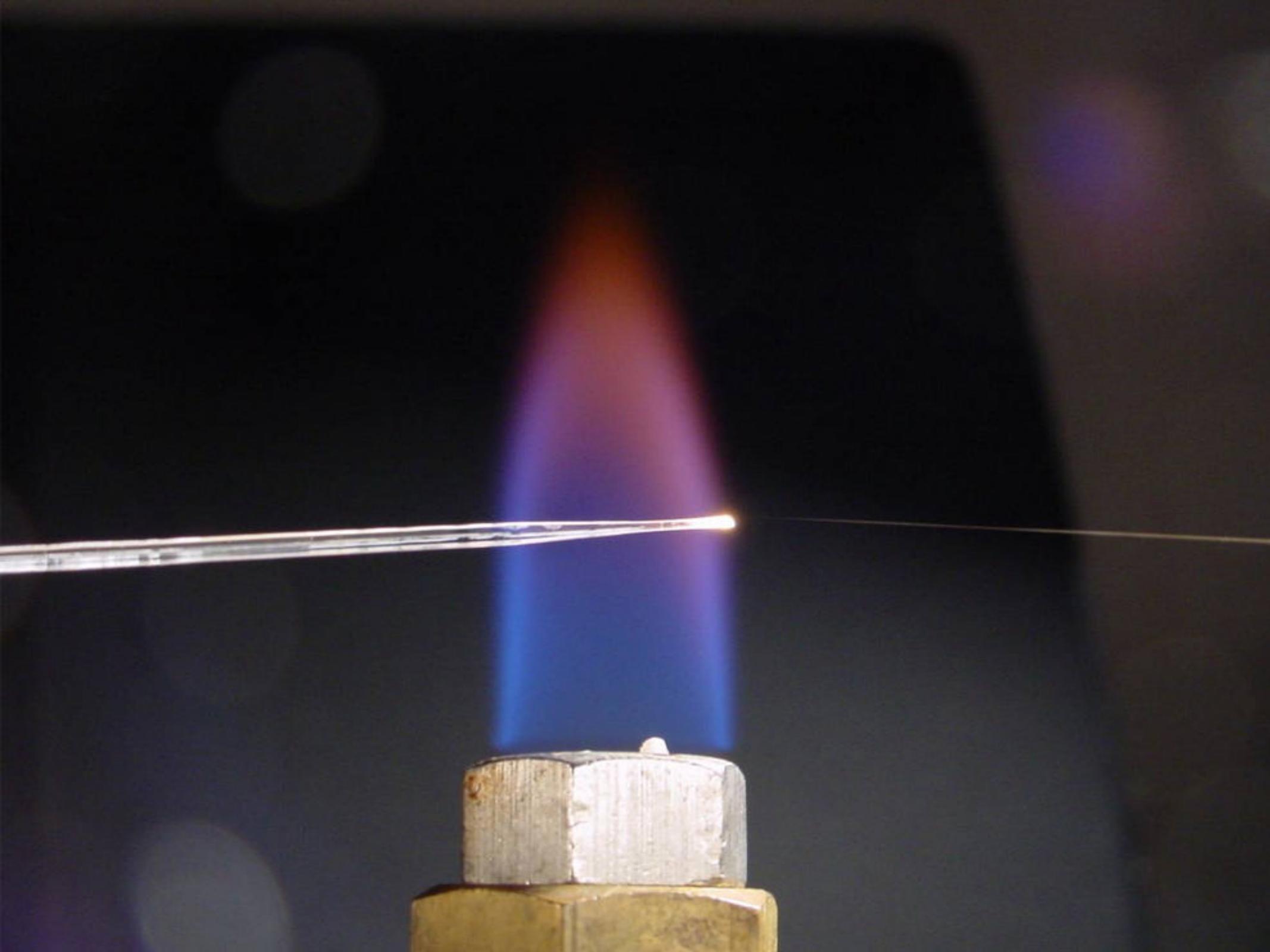
Nanoscale nonlinear optics

nanowire continuum generation

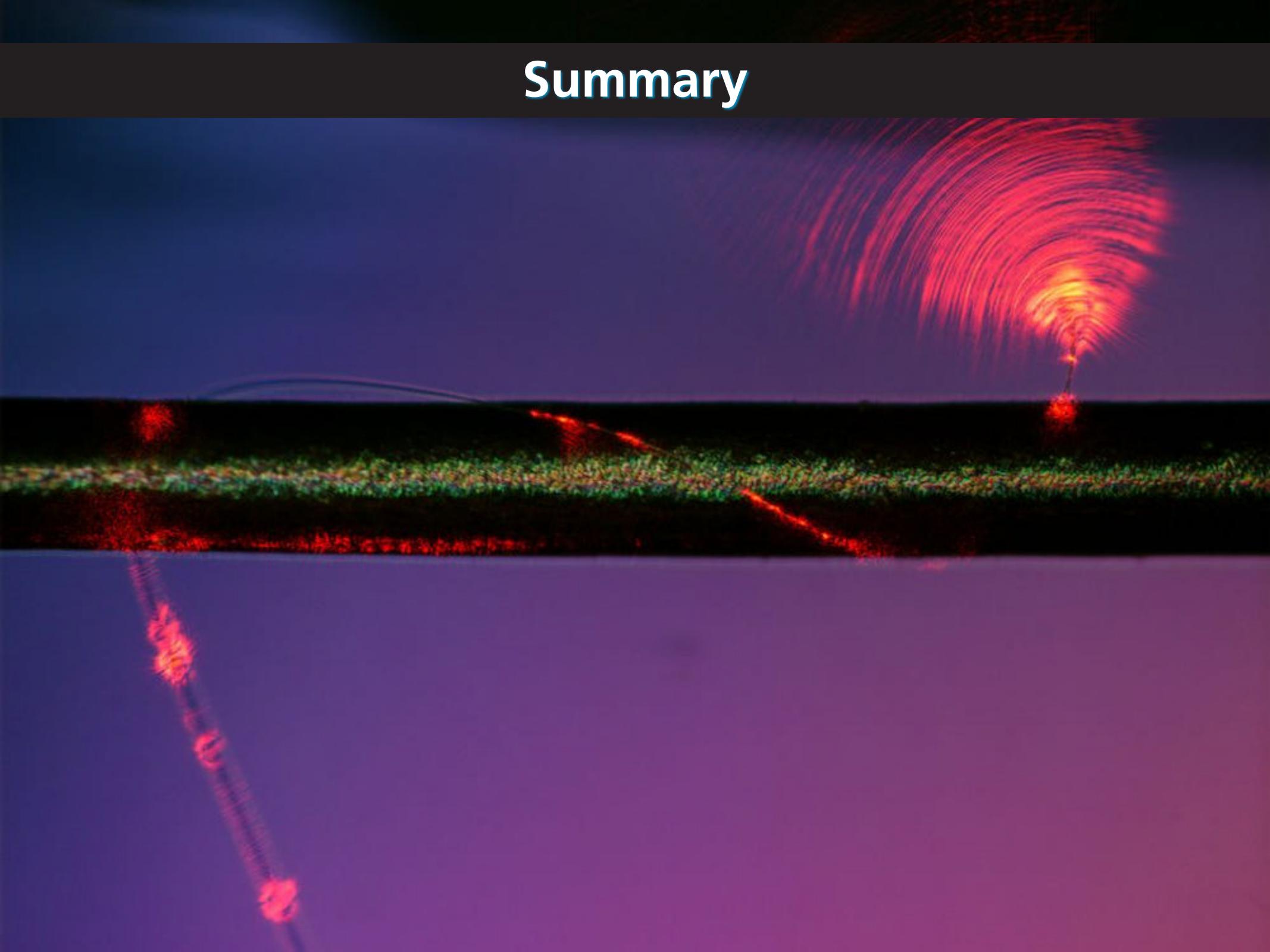


Nanoscale nonlinear optics

energy in nanowire < 100 pJ!



Summary



Summary

- easy fabrication
- convenient nanoscale light manipulation
- nanoscale nonlinear optics





Funding:

Harvard Center for Imaging and Mesoscopic Structures
National Science Foundation
National Natural Science Foundation of China

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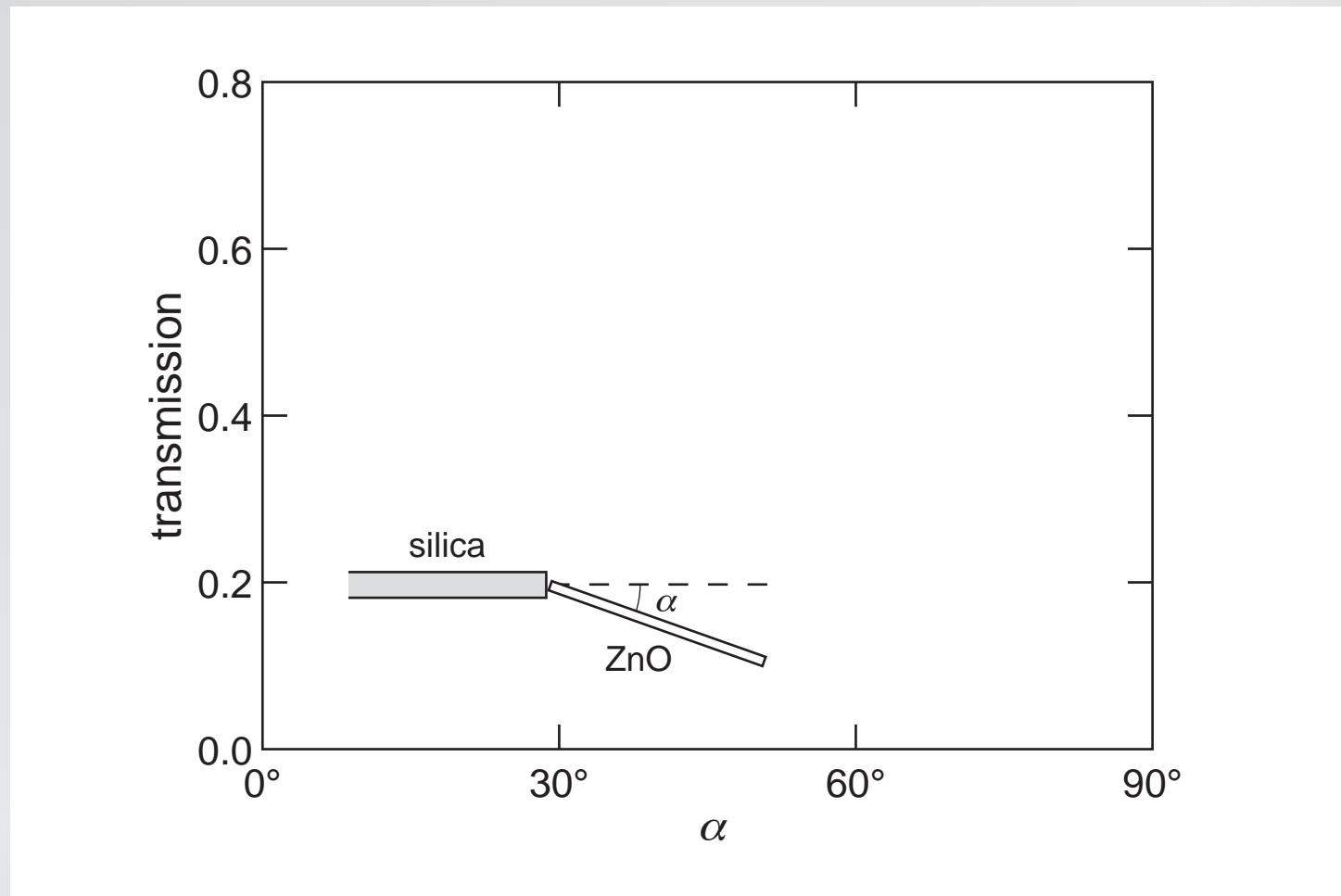
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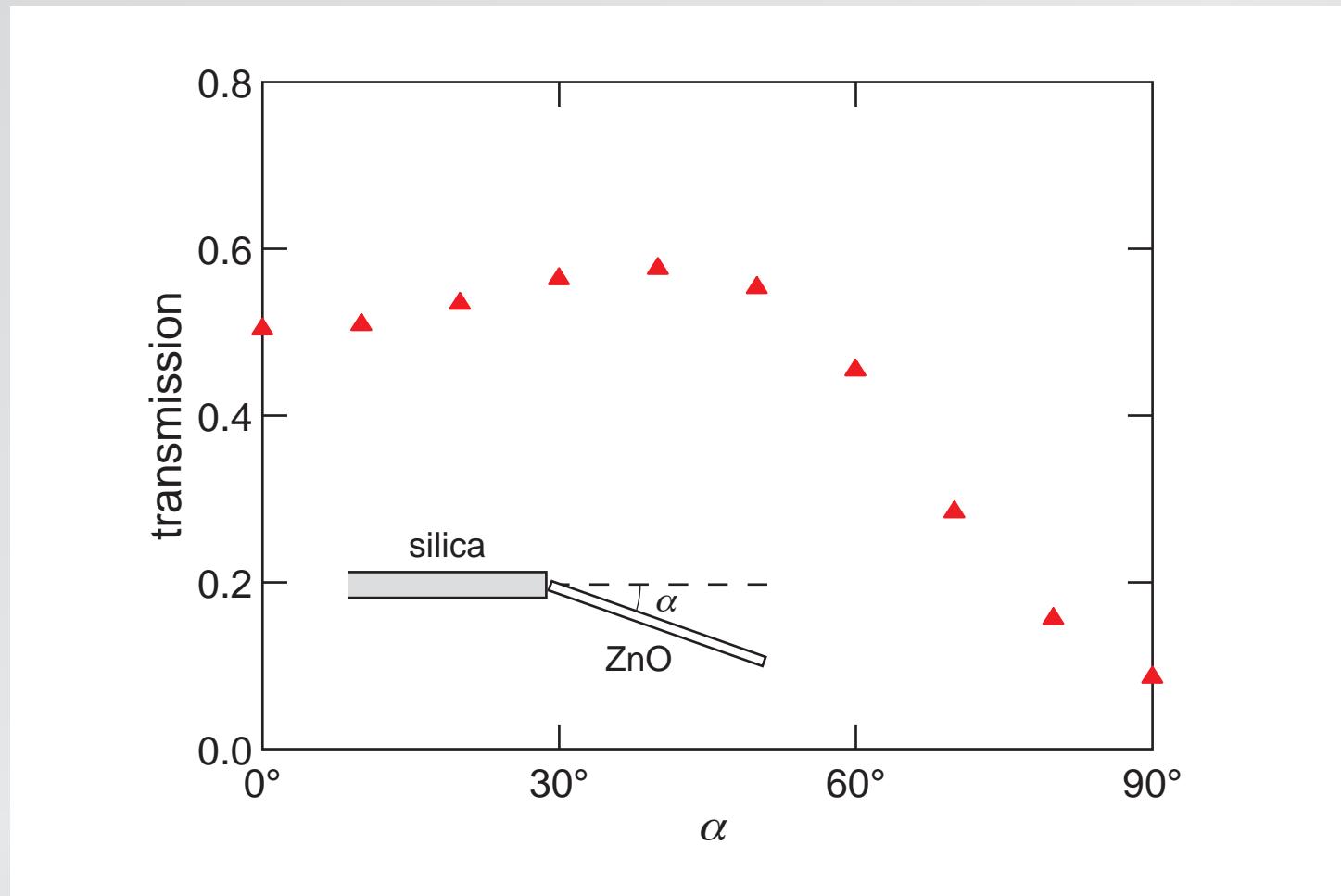
Manipulating light at the nanoscale

coupling efficiency



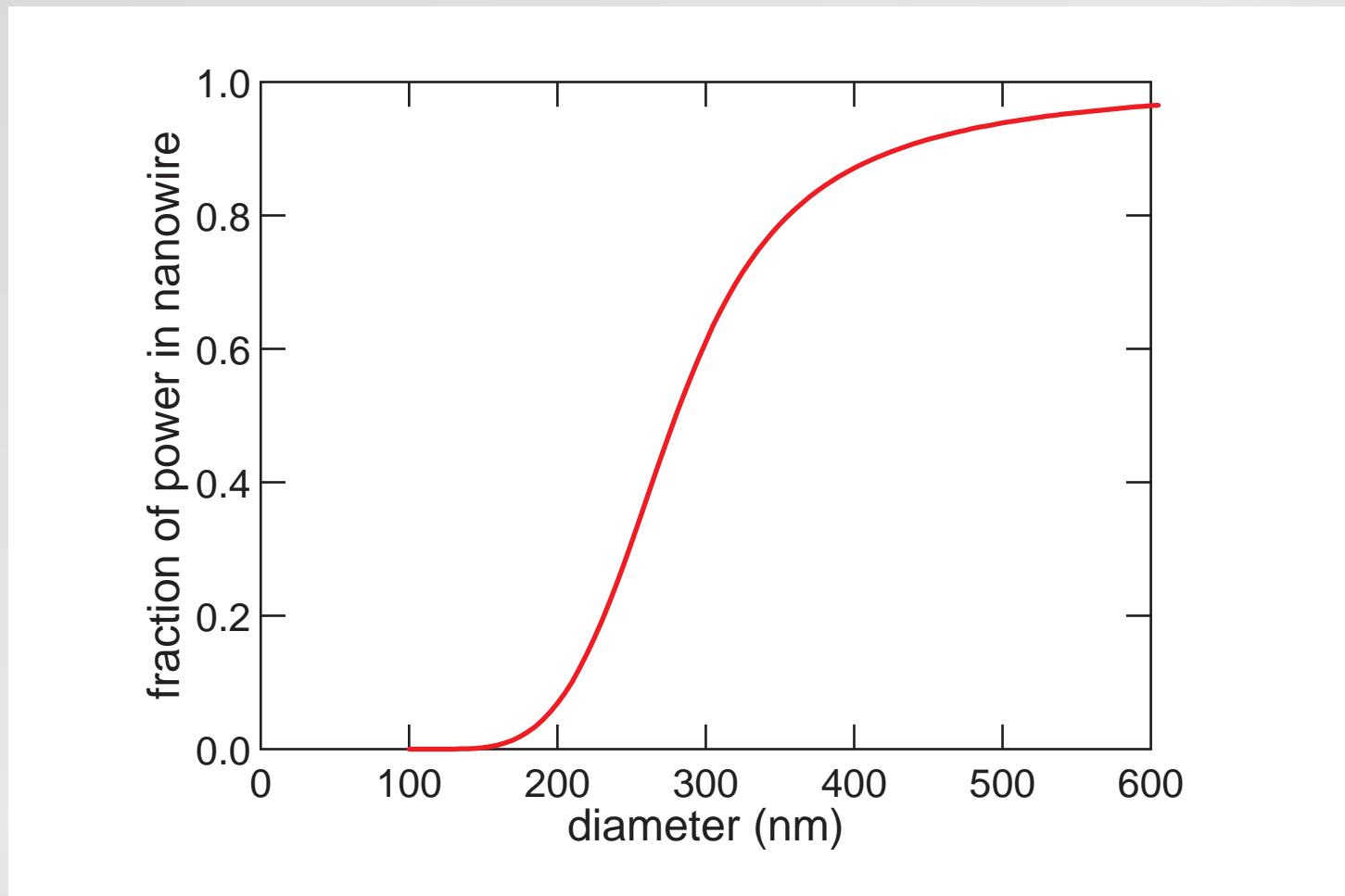
Manipulating light at the nanoscale

coupling efficiency



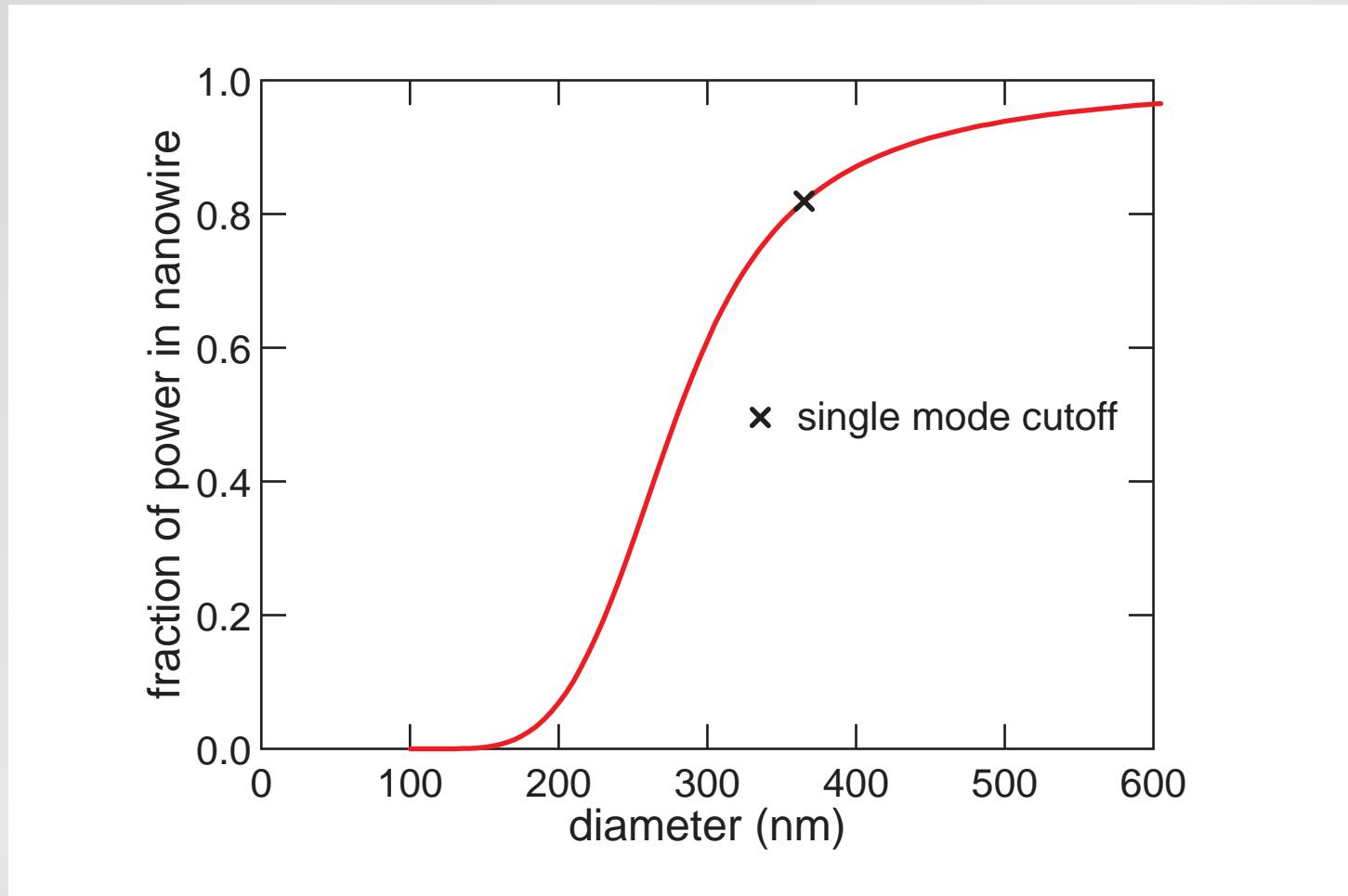
Manipulating light at the nanoscale

single-mode cutoff



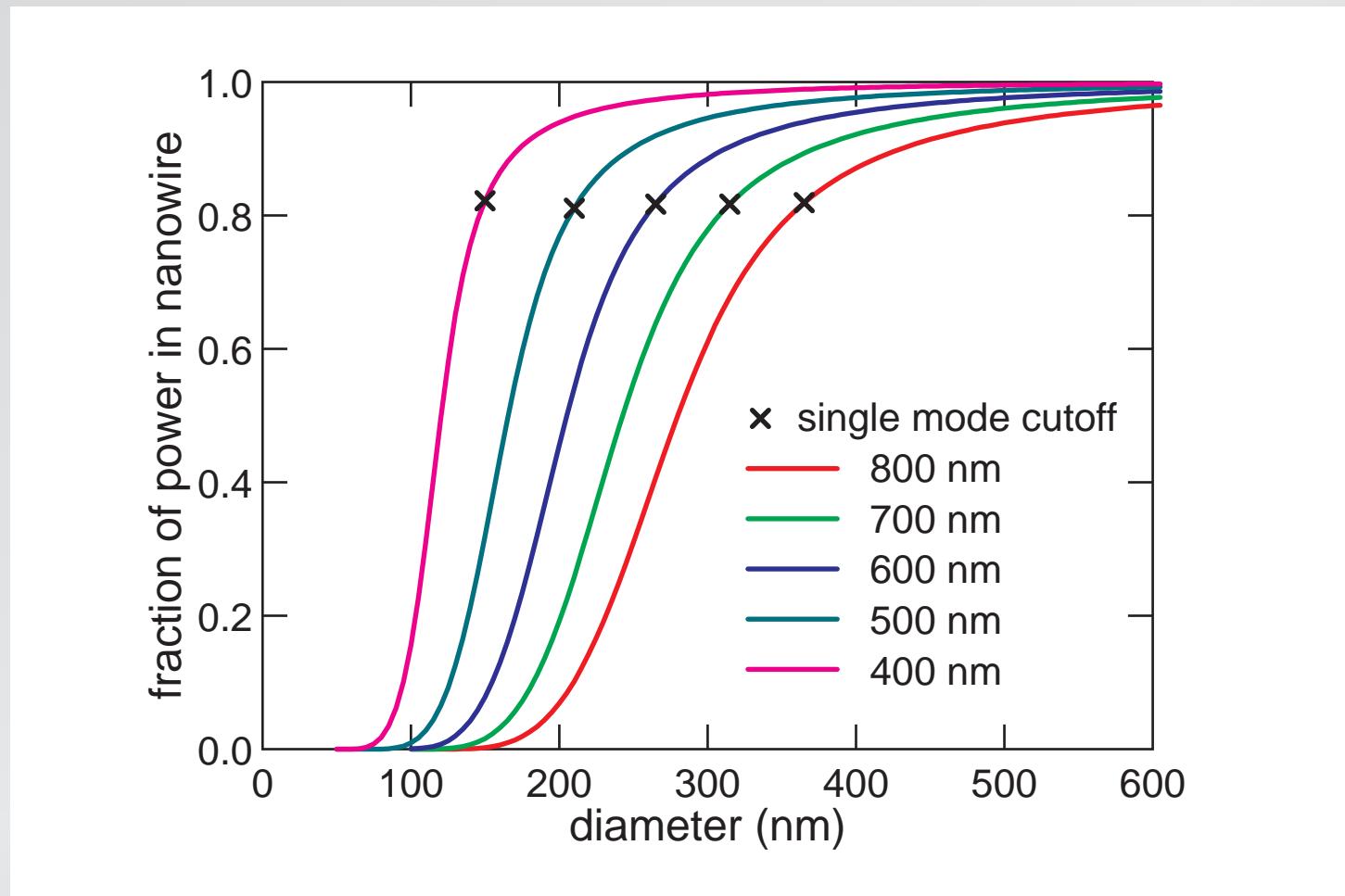
Manipulating light at the nanoscale

single-mode cutoff



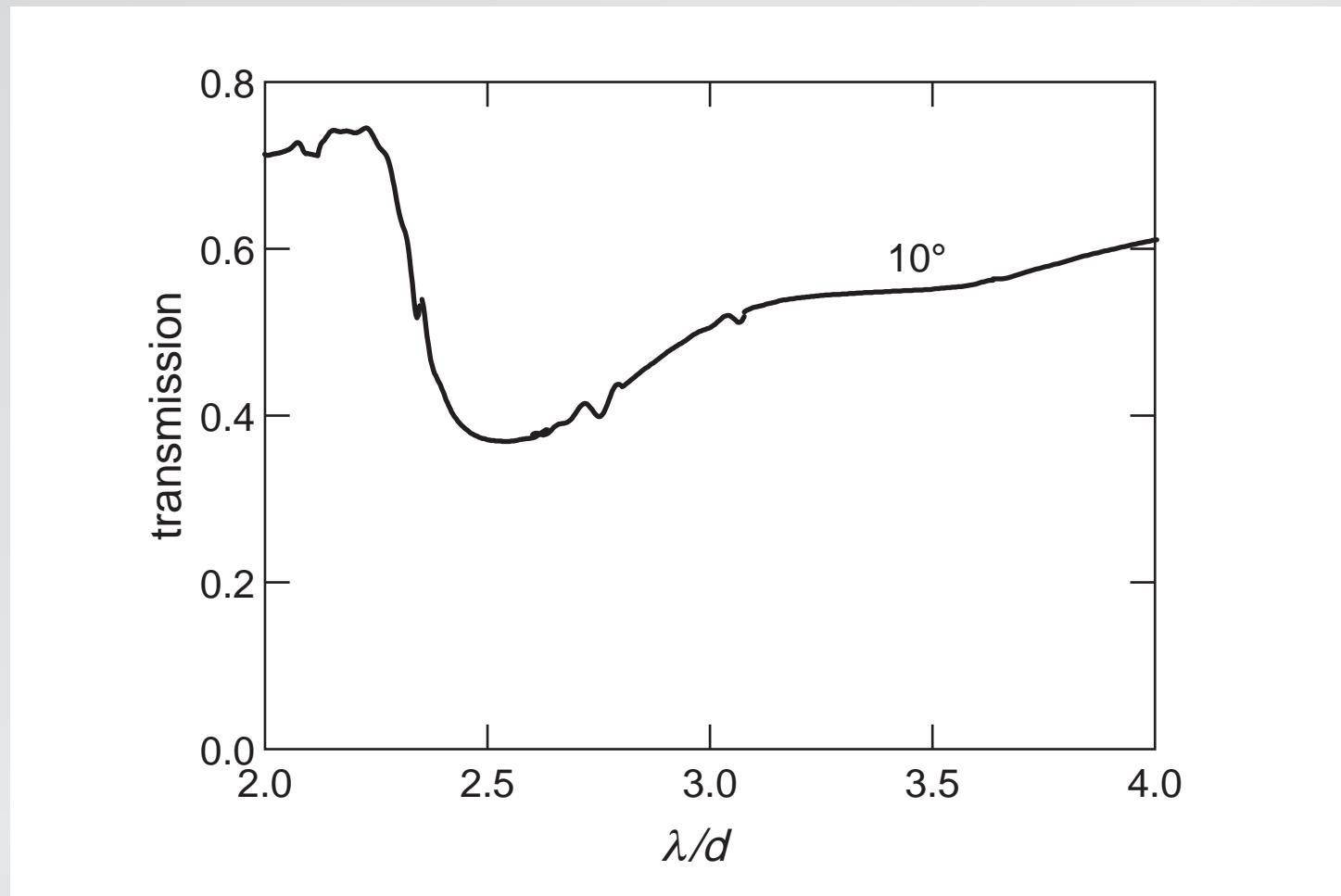
Manipulating light at the nanoscale

single-mode cutoff



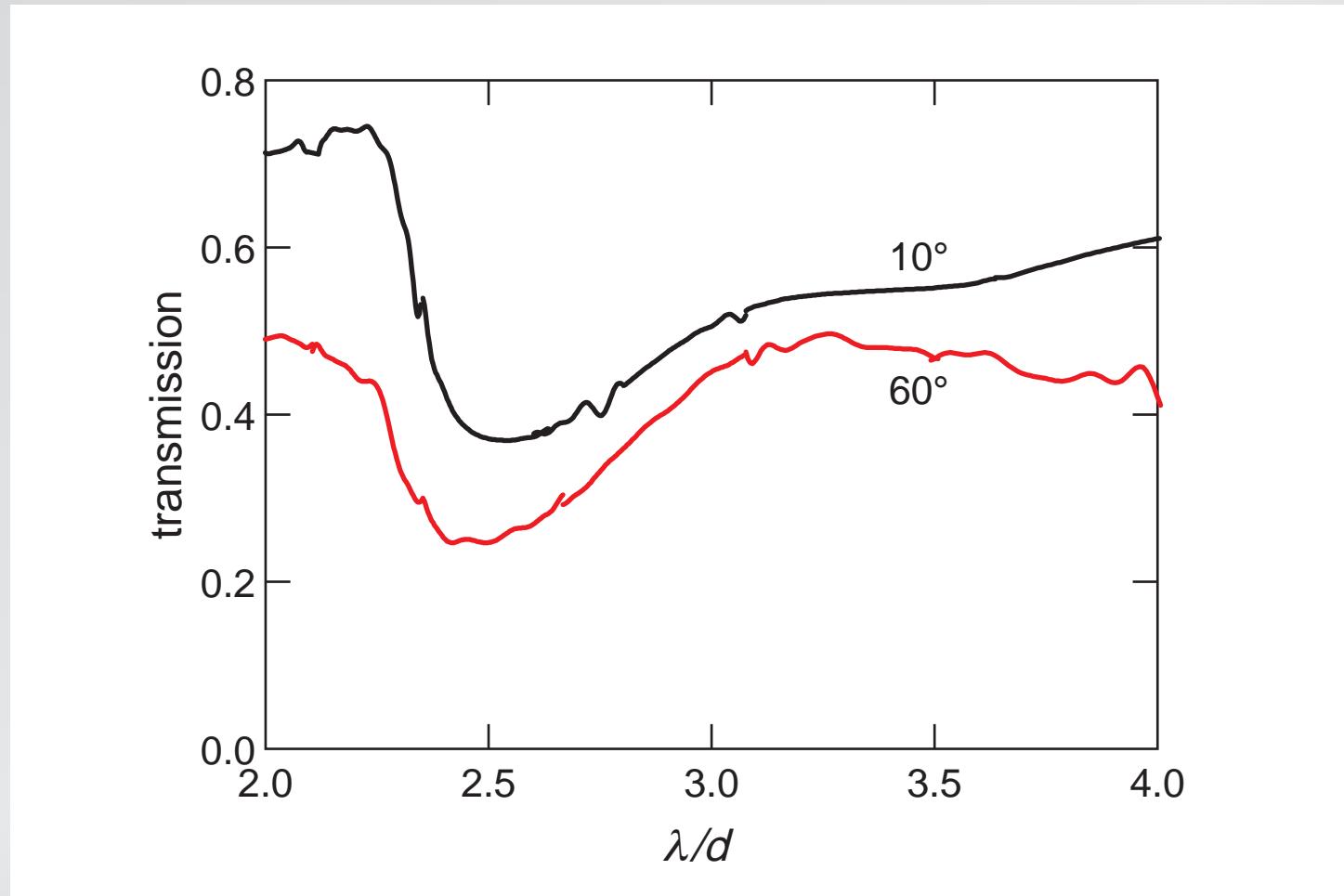
Manipulating light at the nanoscale

transmission spectrum



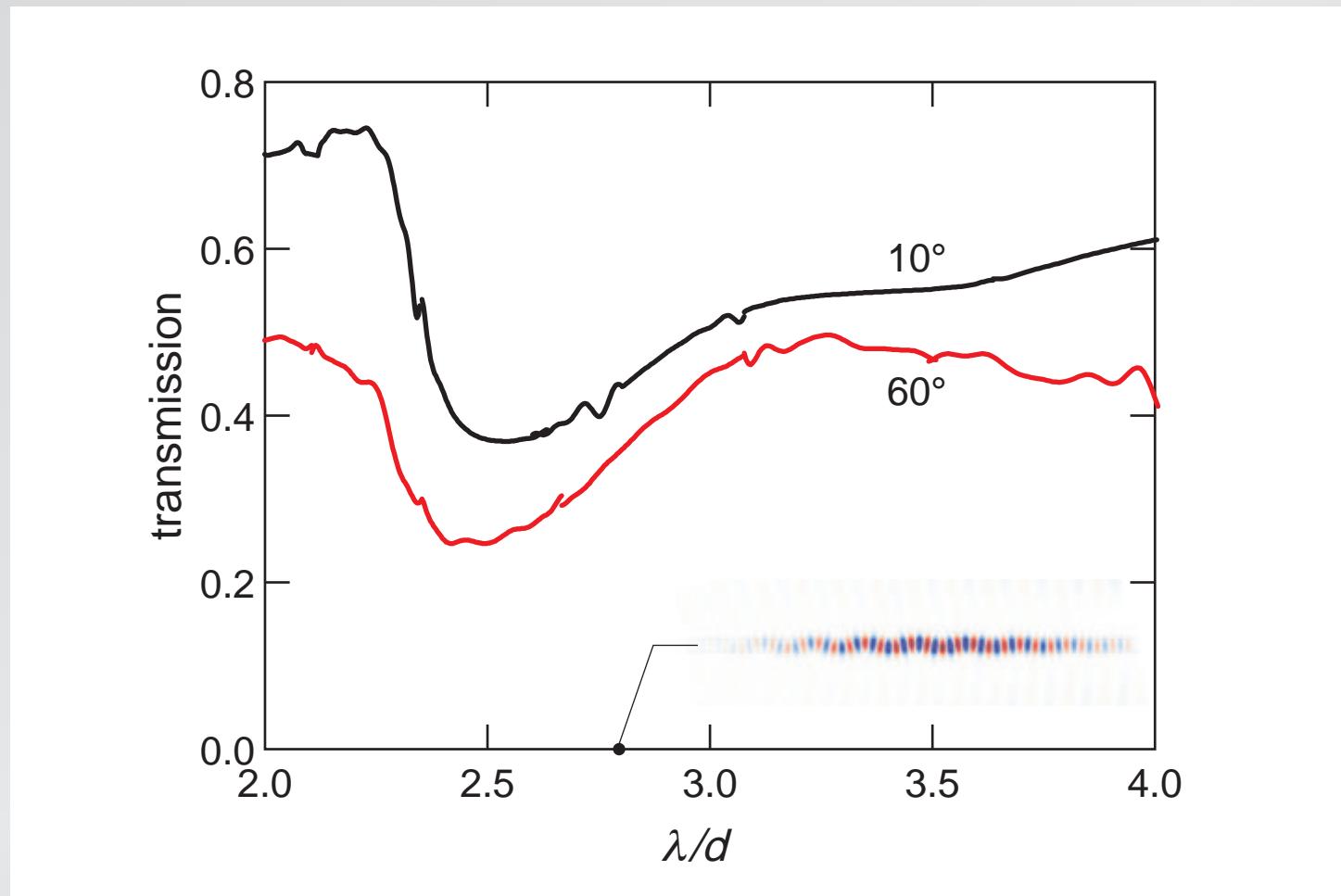
Manipulating light at the nanoscale

transmission spectrum



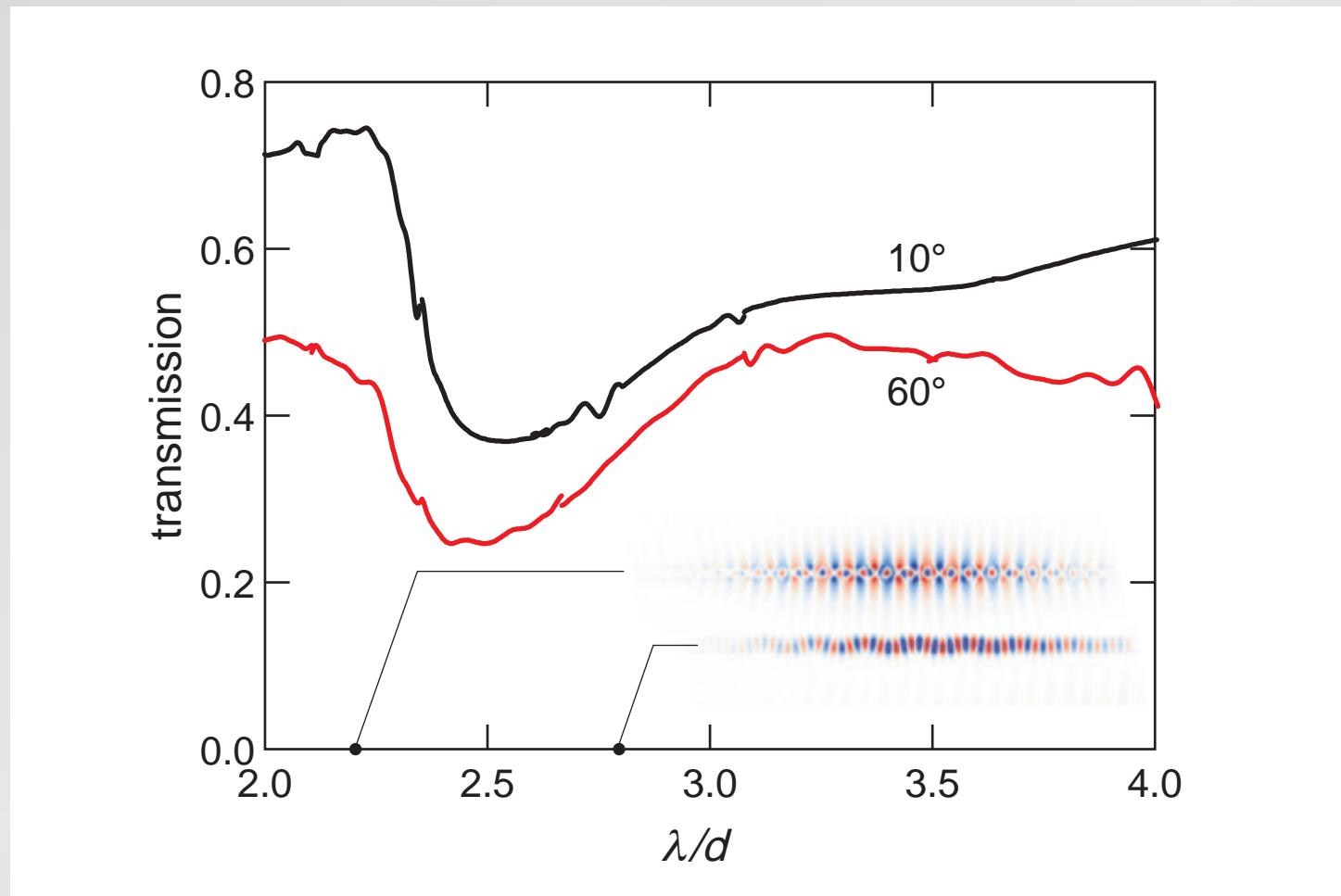
Manipulating light at the nanoscale

transmission spectrum



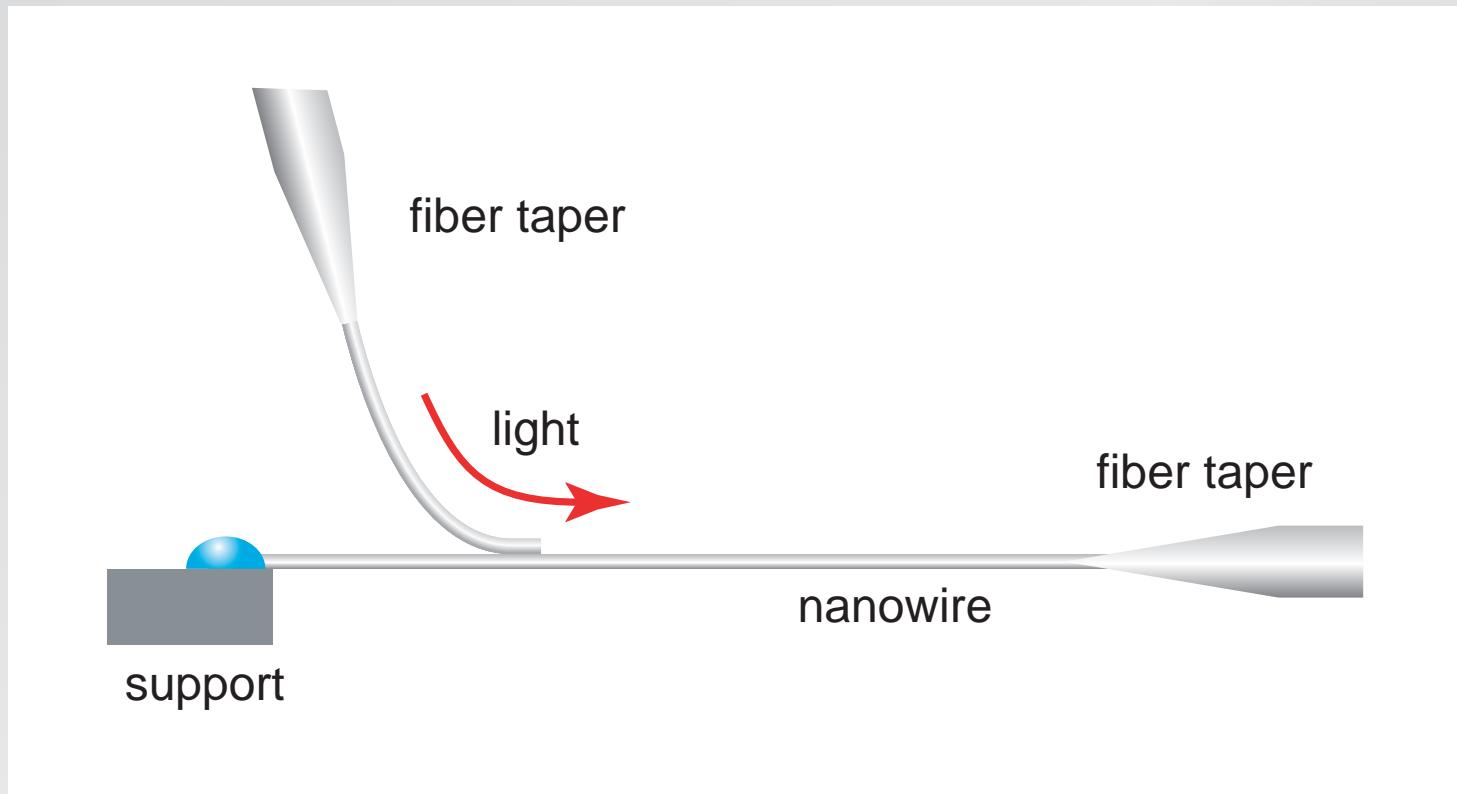
Manipulating light at the nanoscale

transmission spectrum



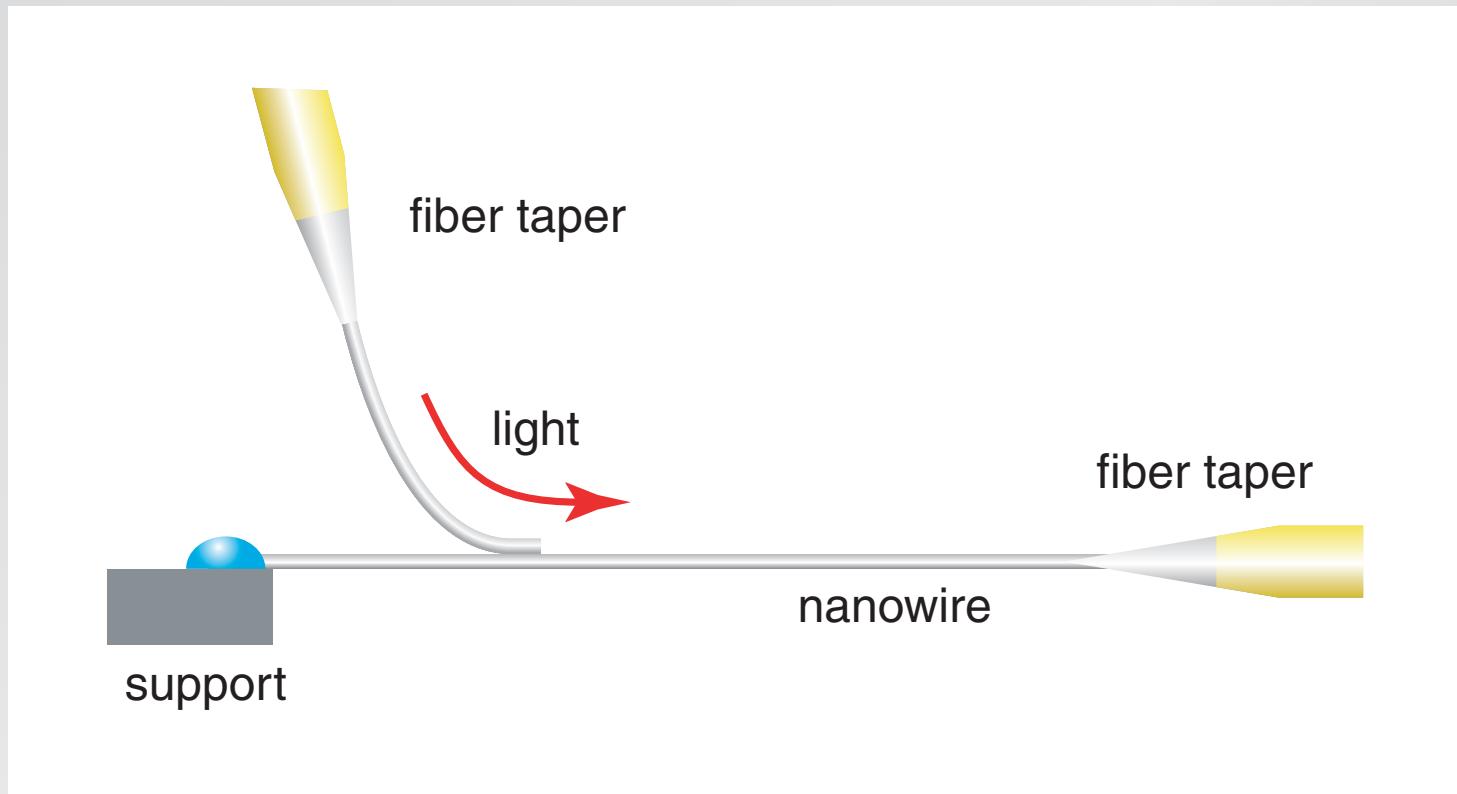
Manipulating light at the nanoscale

loss measurement



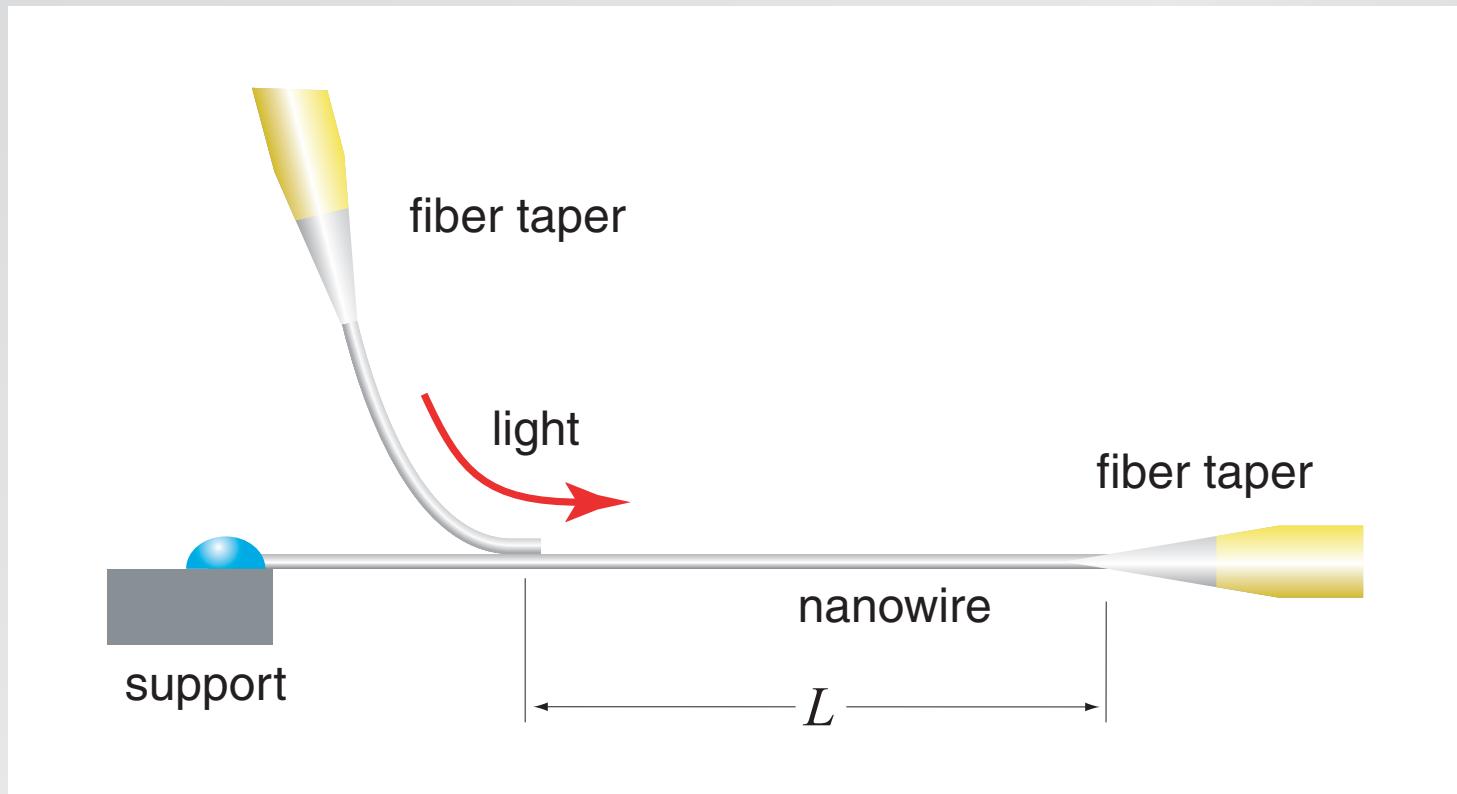
Manipulating light at the nanoscale

loss measurement



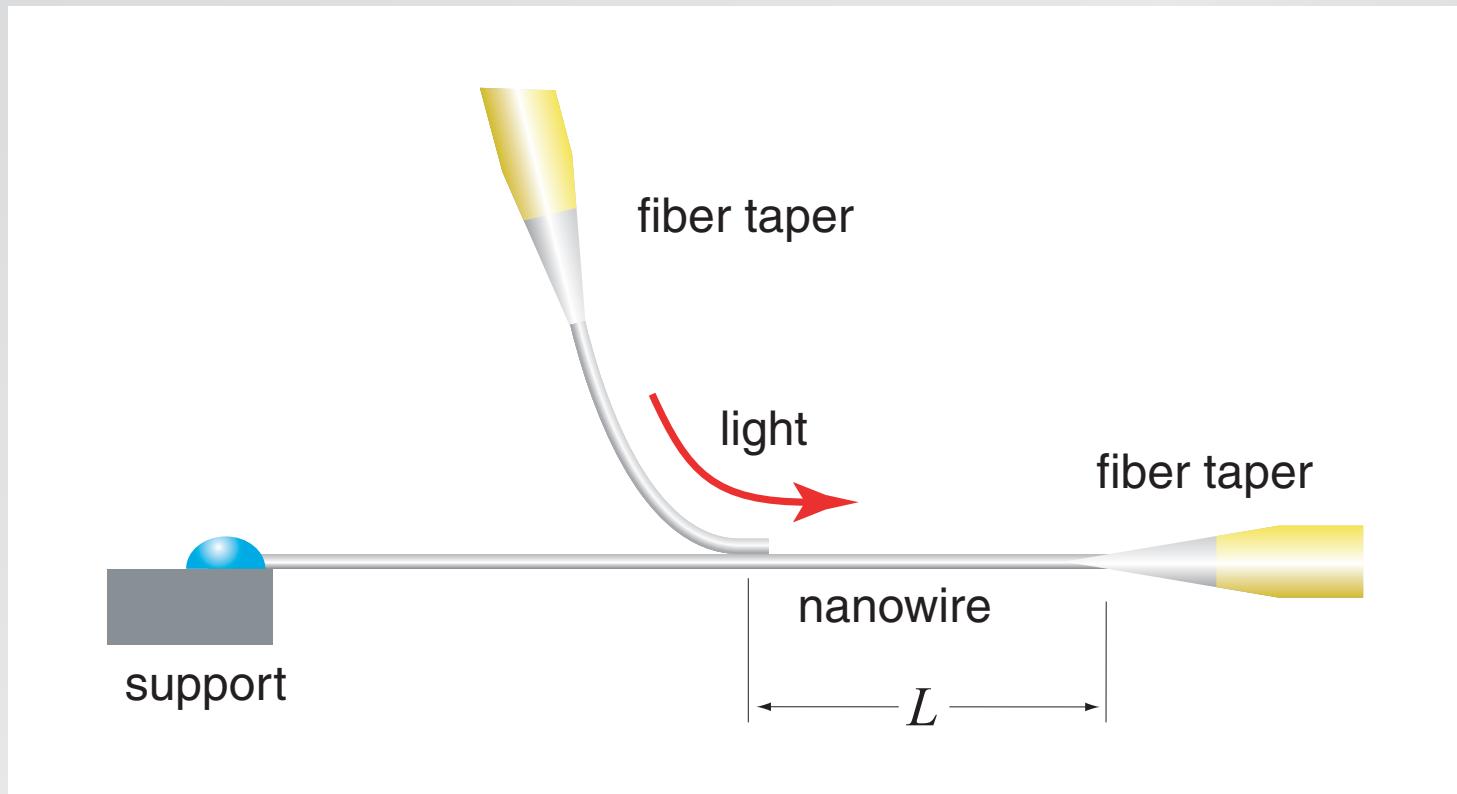
Manipulating light at the nanoscale

loss measurement



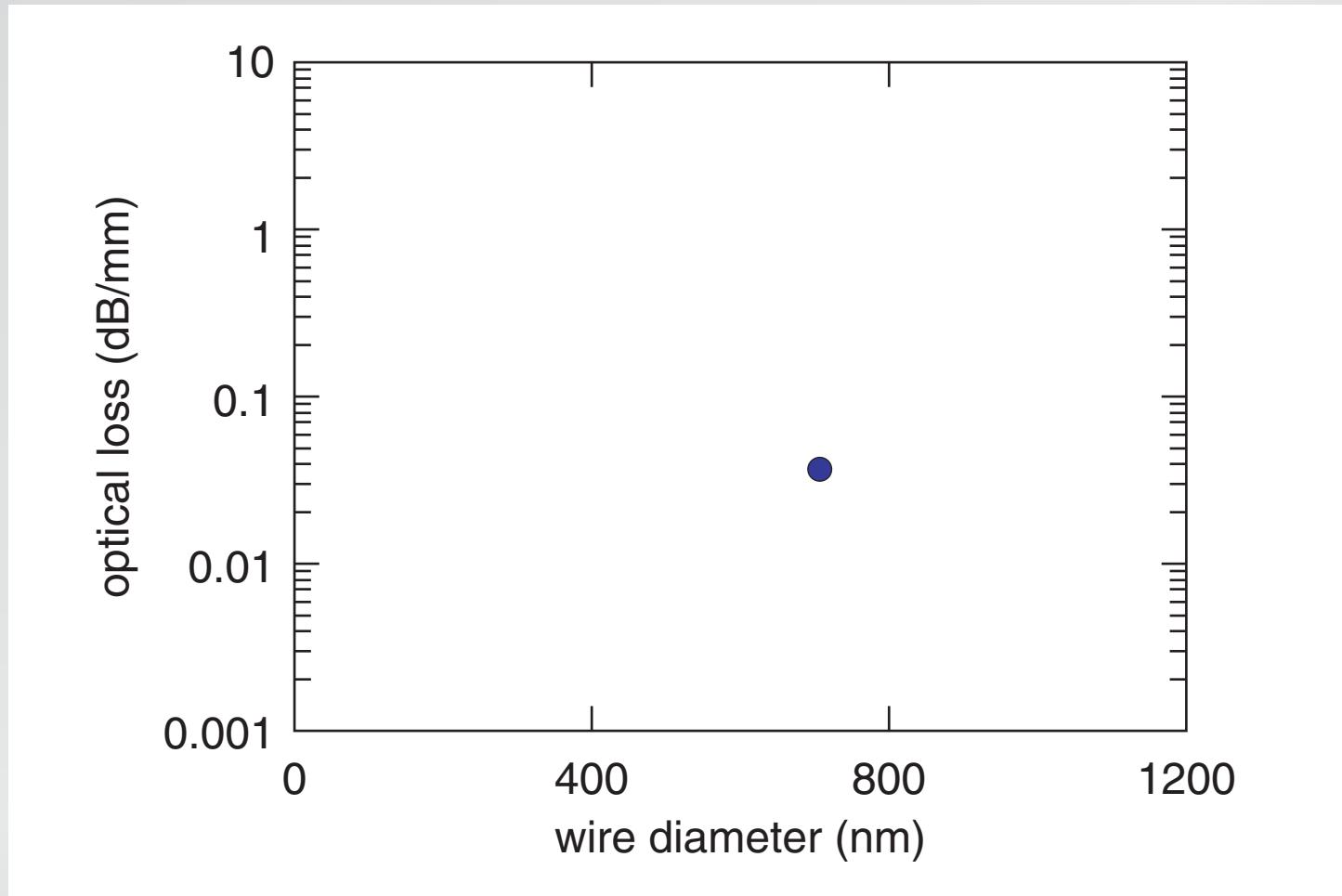
Manipulating light at the nanoscale

loss measurement



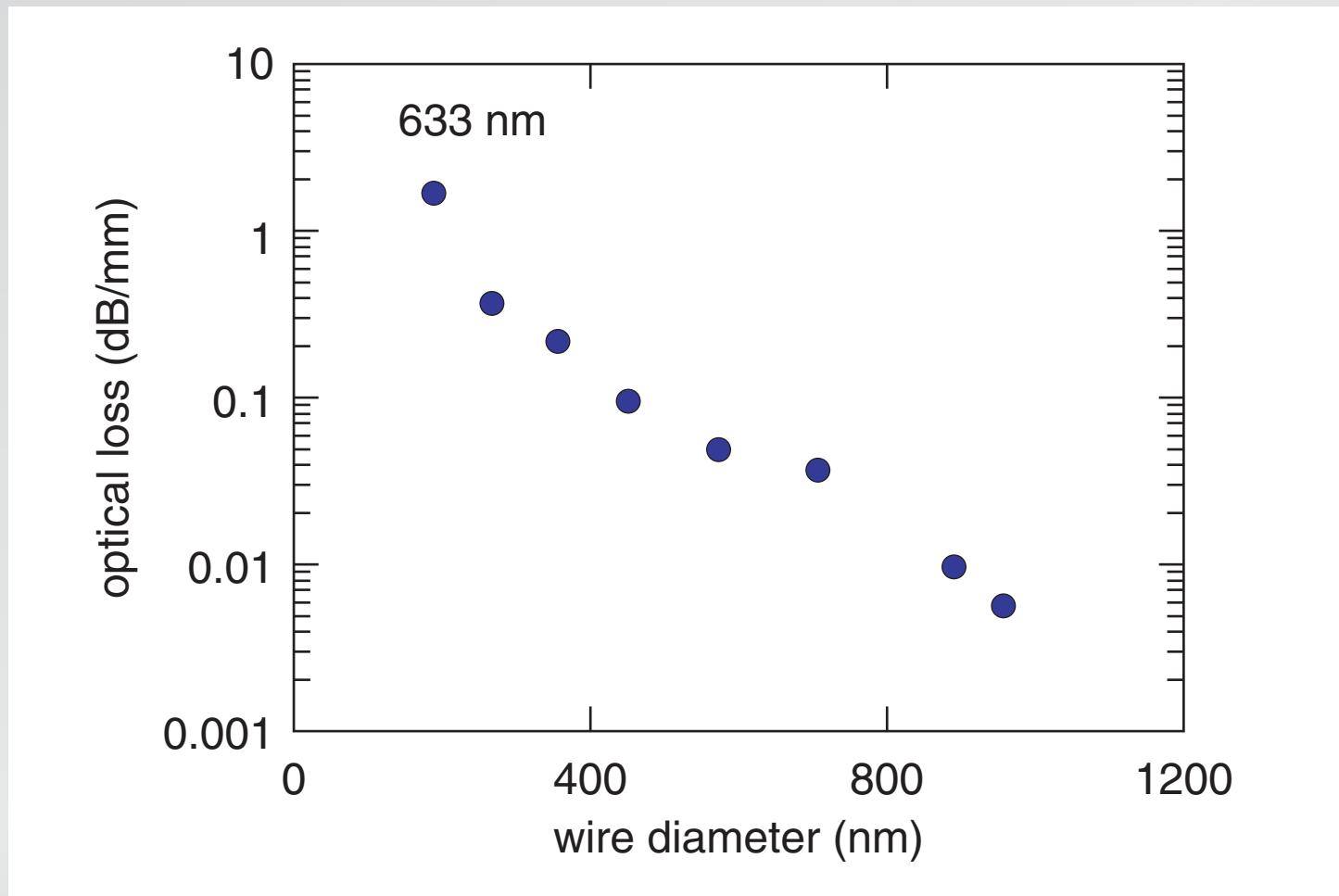
Manipulating light at the nanoscale

loss measurement



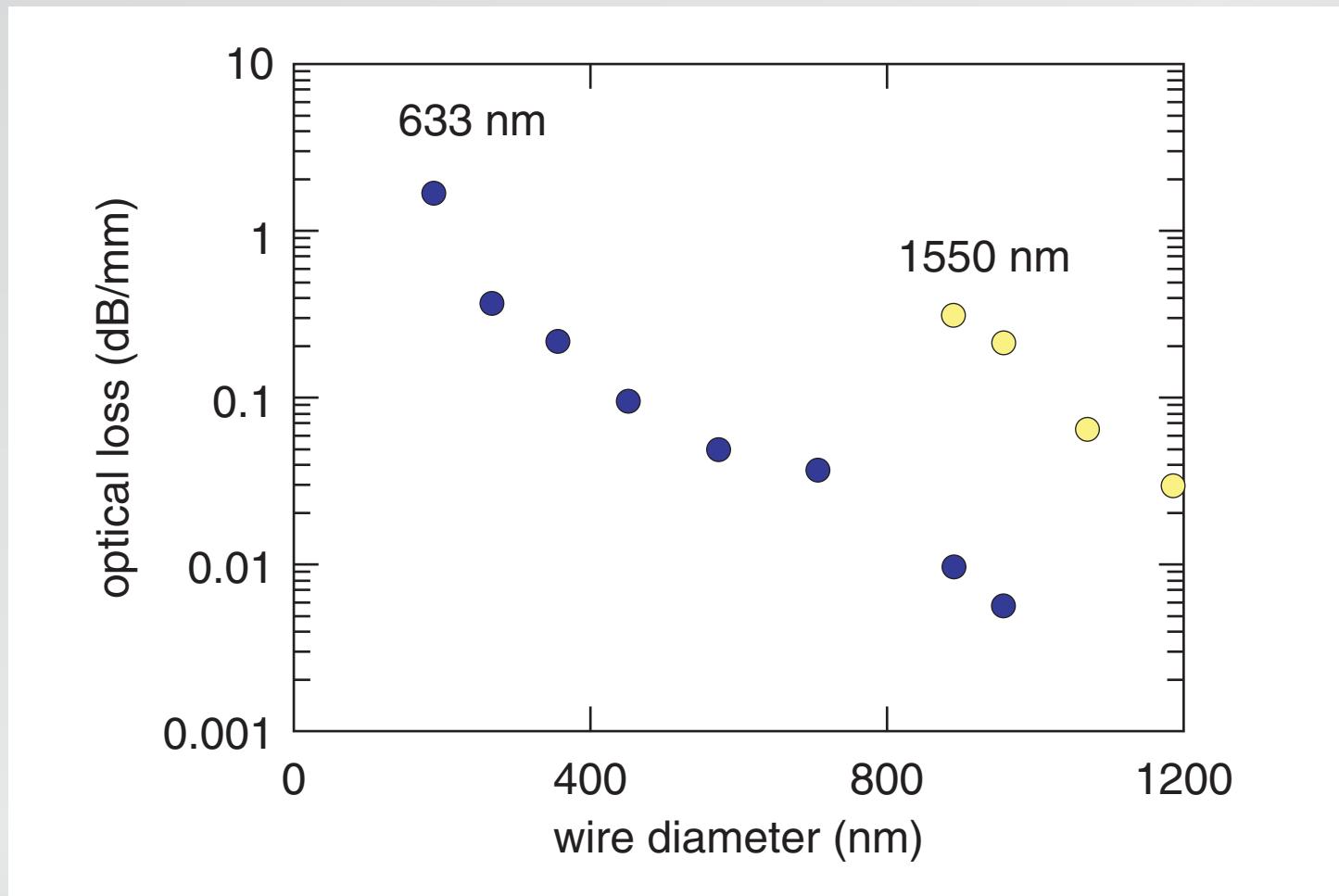
Manipulating light at the nanoscale

loss measurement



Manipulating light at the nanoscale

loss measurement



Manipulating light at the nanoscale

loss at single-mode diameter < 0.1 dB/mm

